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(54) **LED UNIT FOR DISPLAY AND DISPLAY APPARATUS HAVING THE SAME**

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H01L 33/42 (2006.01)

H01L 33/50 (2006.01)

H01L 33/10 (2006.01)

H01L 25/13 (2006.01)

(71) Applicant: **SEOUL VIOSYS CO., LTD.**, Ansan-si (KR)

(72) Inventors: **Jong Hyeon Chae**, Ansan-si (KR); **Seong Gyu Jang**, Ansan-si (KR); **Ho Joon Lee**, Ansan-si (KR); **Chang Yeon Kim**, Ansan-si (KR); **Chung Hoon Lee**, Ansan-si (KR)

(52) **U.S. Cl.**

CPC *H01L 27/156* (2013.01); *H01L 33/405* (2013.01); *H01L 33/38* (2013.01); *H01L 25/13* (2013.01); *H01L 33/507* (2013.01); *H01L 33/10* (2013.01); *H01L 33/42* (2013.01)

(21) Appl. No.: **16/198,792**

(22) Filed: **Nov. 22, 2018**

(57)

ABSTRACT

Related U.S. Application Data

(60) Provisional application No. 62/590,870, filed on Nov. 27, 2017, provisional application No. 62/590,854, filed on Nov. 27, 2017, provisional application No. 62/594,769, filed on Dec. 5, 2017, provisional application No. 62/595,932, filed on Dec. 7, 2017, provisional application No. 62/608,297, filed on Dec. 20, 2017, provisional application No. 62/614,900, filed on Jan. 8, 2018, provisional application No. 62/635,284, filed on Feb. 26, 2018, provisional application No. 62/683,564, filed on Jun. 11, 2018.

A light emitting device including first, second, and third LED sub-units, and electrode pads disposed on the first LED sub-unit, electrically connected to the LED sub-units, and including a common electrode pad electrically connected to each of the LED sub-units, and first, second, and third electrode pads connected to a respective one of the LED sub-units, in which the common electrode pad, the second electrode pad, and the third electrode pad are electrically connected to the second LED sub-unit and the third LED sub-unit through holes that pass through the first LED sub-unit, the first, second, and third LED sub-units are configured to be independently driven, light generated in the first LED sub-unit emitted to the outside through the second and third LED sub-units, and light generated in the second LED sub-unit is emitted to the outside through the third LED sub-unit.

Publication Classification

(51) **Int. Cl.**

H01L 27/15 (2006.01)

H01L 33/40 (2006.01)

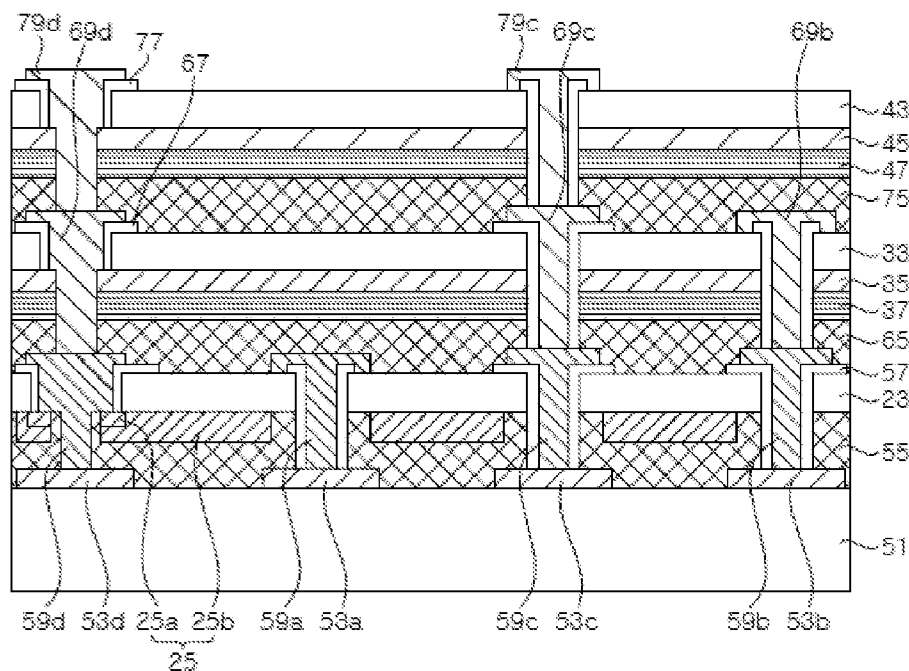


FIG. 1

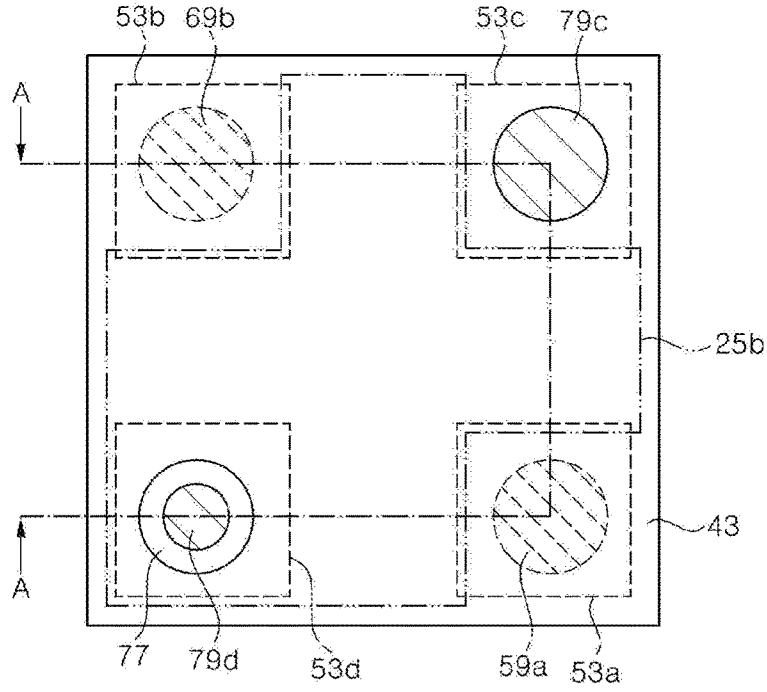


FIG. 2

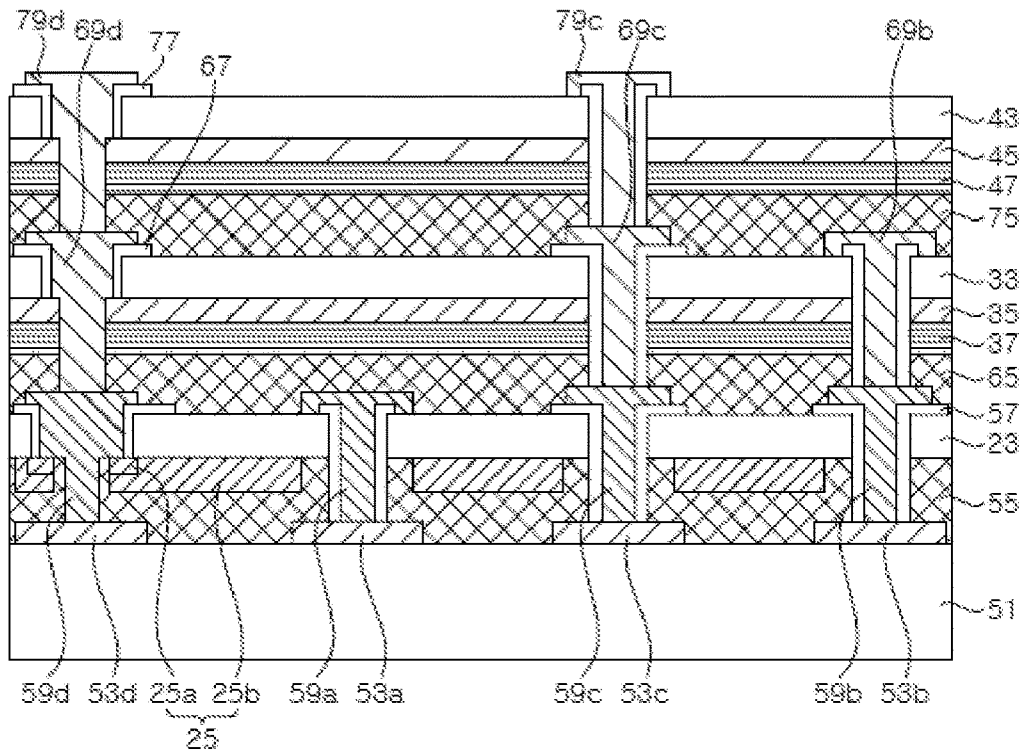


FIG. 3A

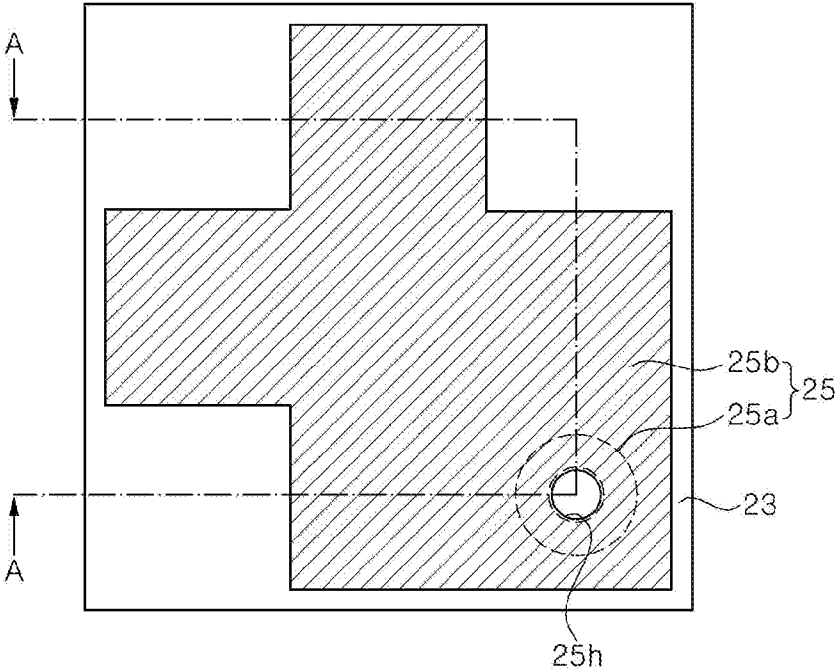


FIG. 3B

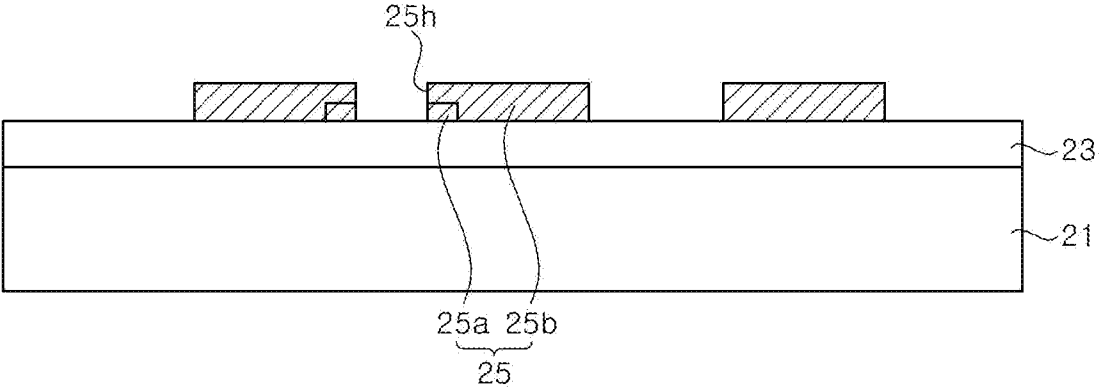


FIG. 4A

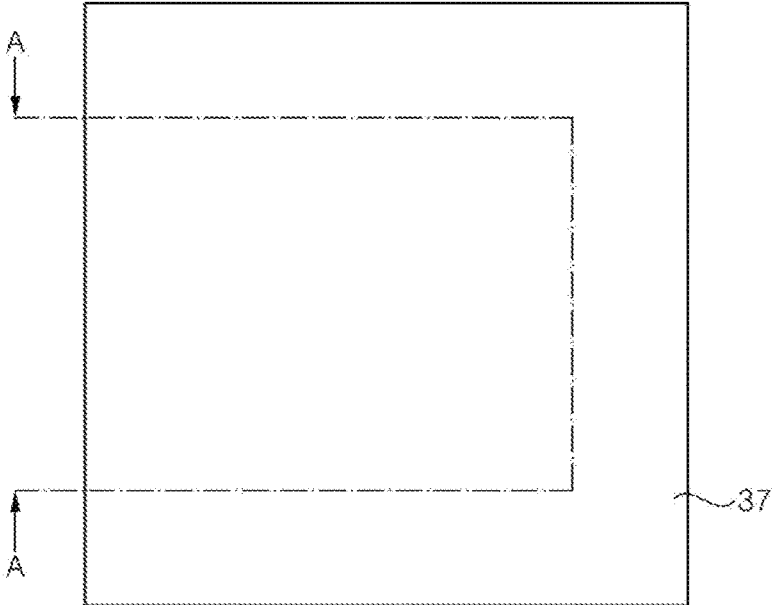


FIG. 4B

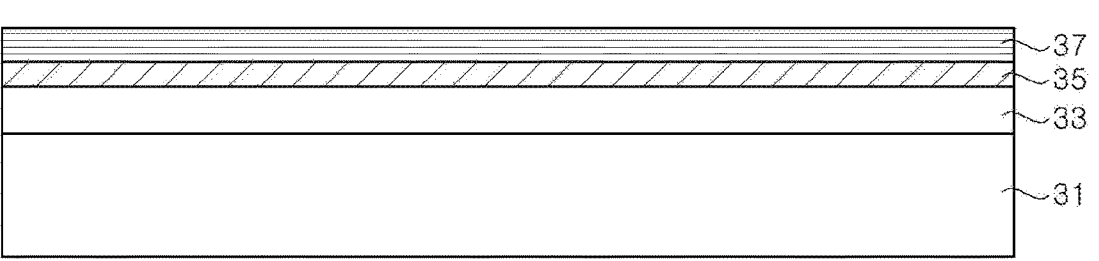


FIG. 5A

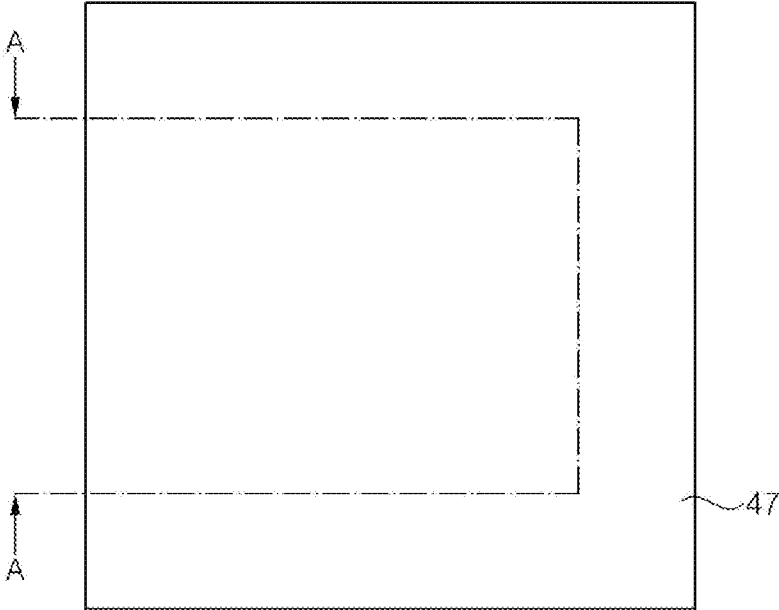


FIG. 5B

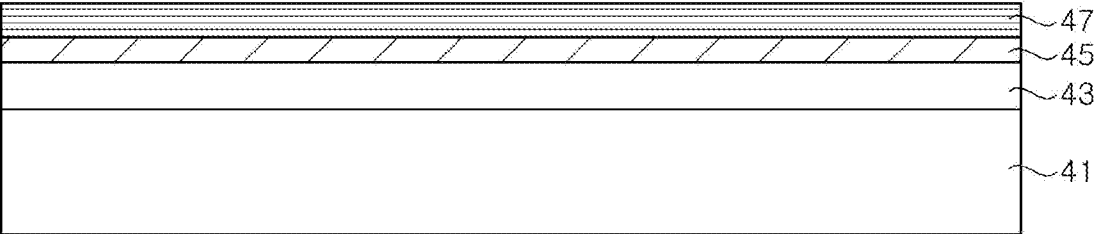


FIG. 6A

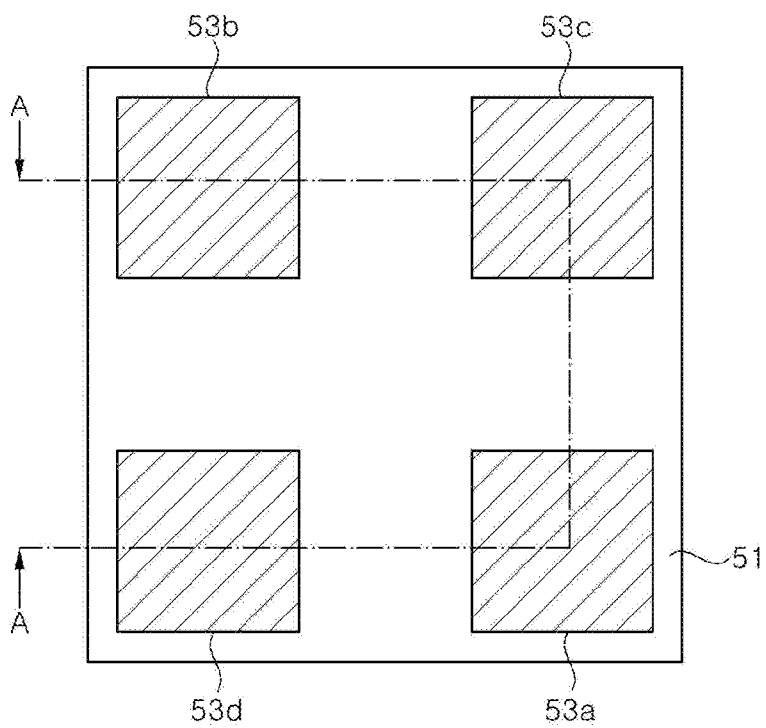


FIG. 6B

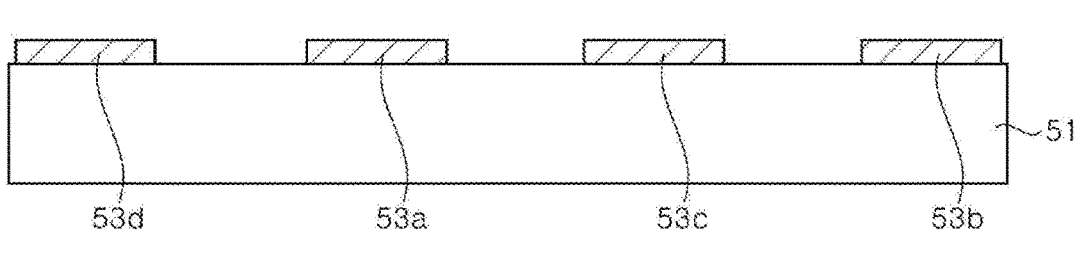


FIG. 7A

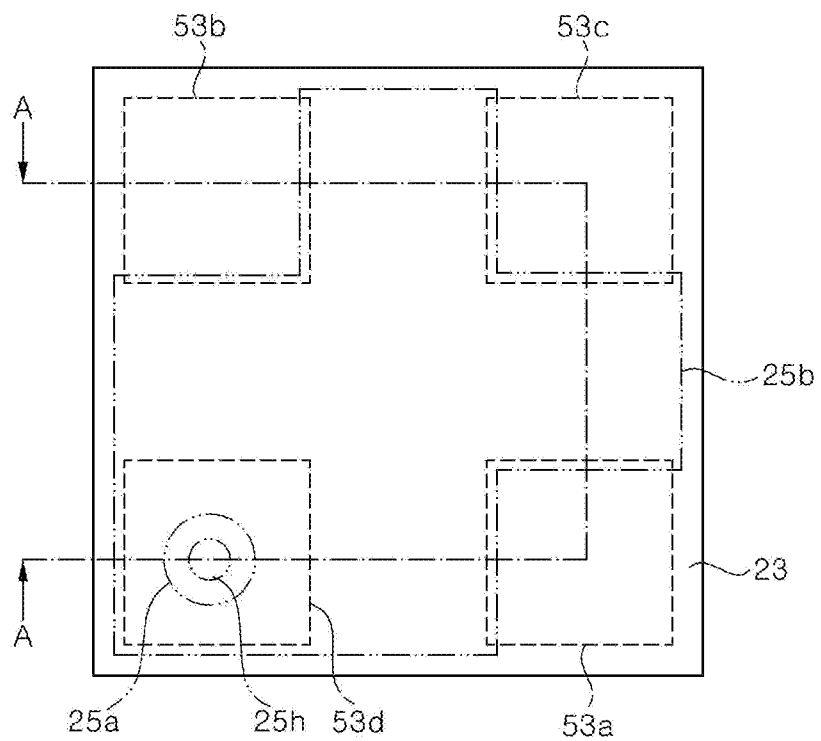


FIG. 7B

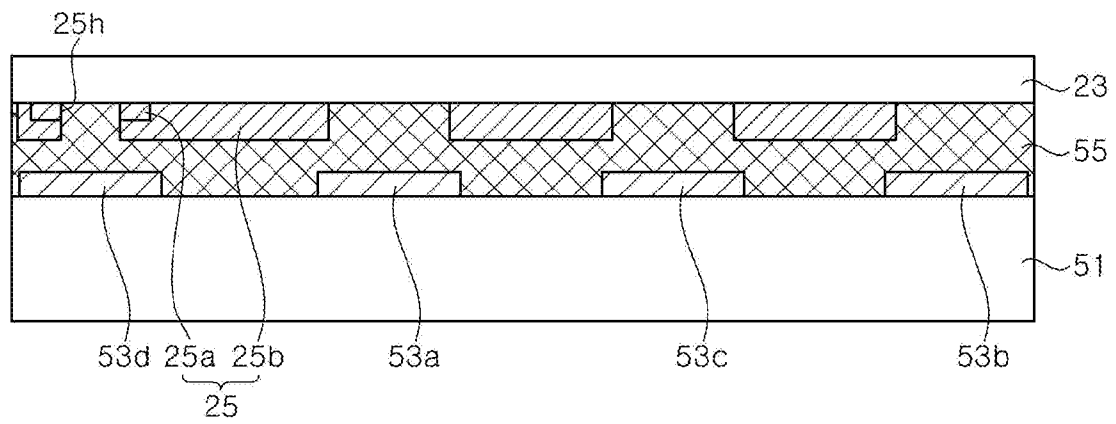


FIG. 8A

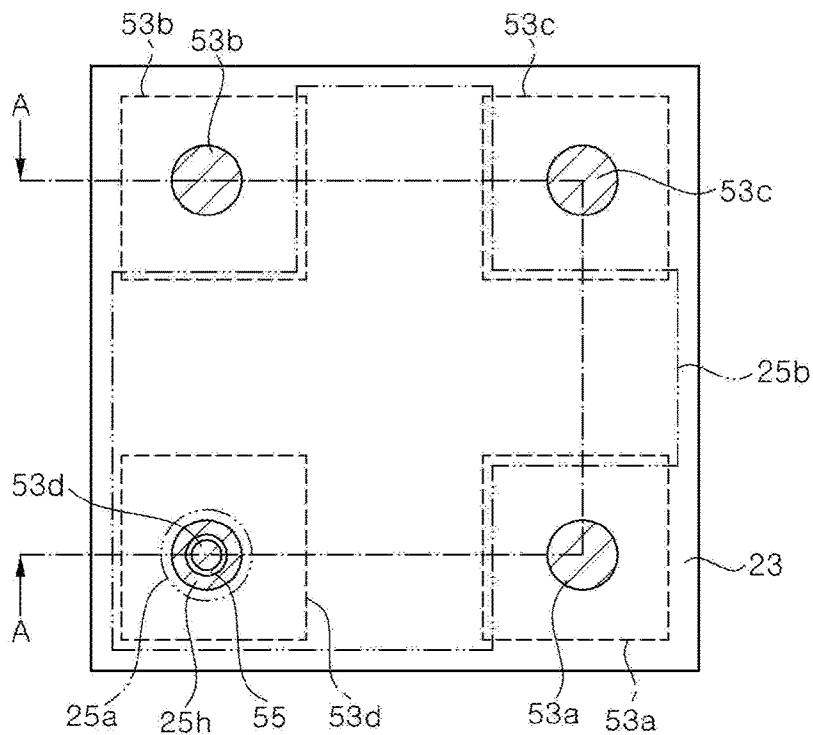


FIG. 8B

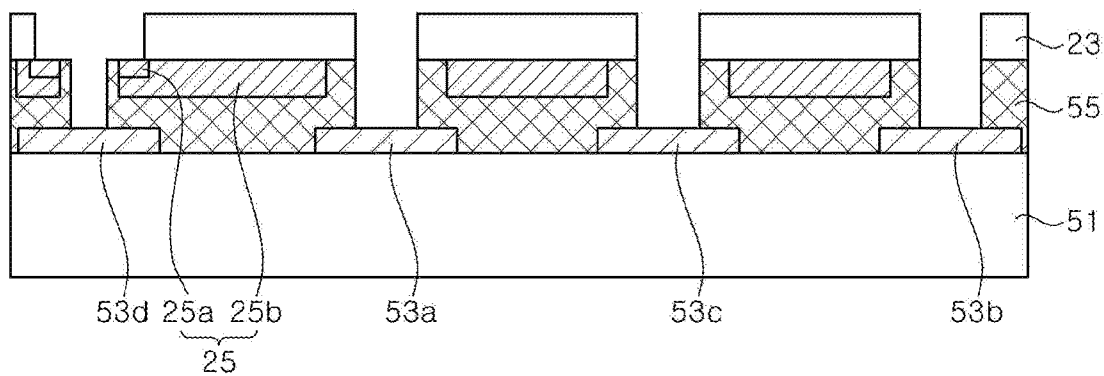


FIG. 9A

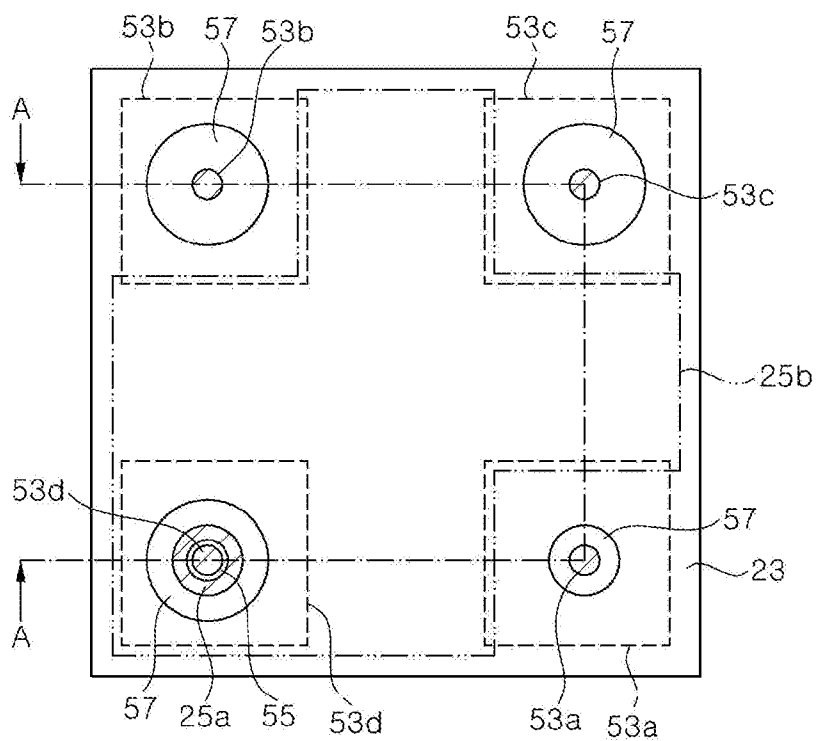


FIG. 9B

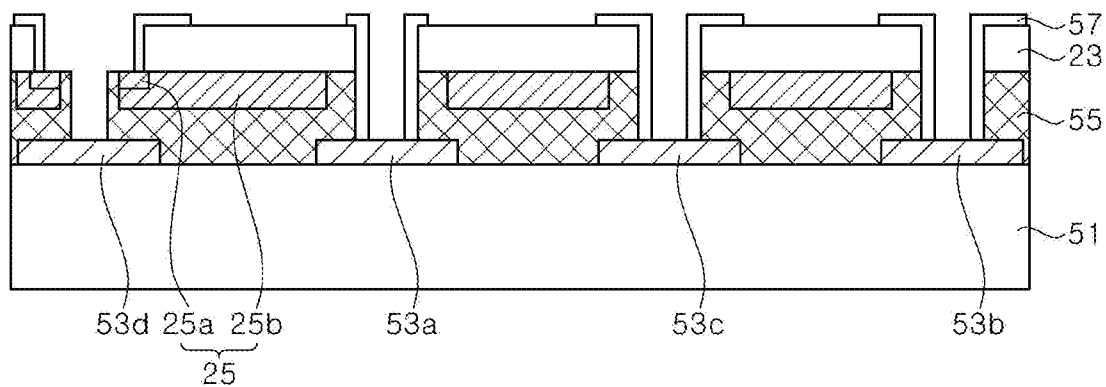


FIG. 10A

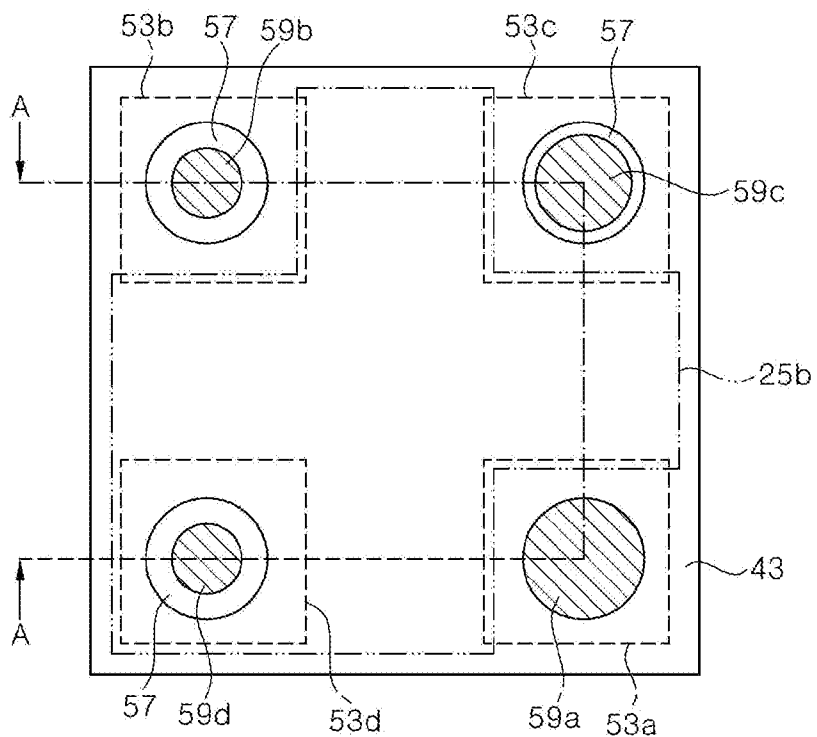


FIG. 10B

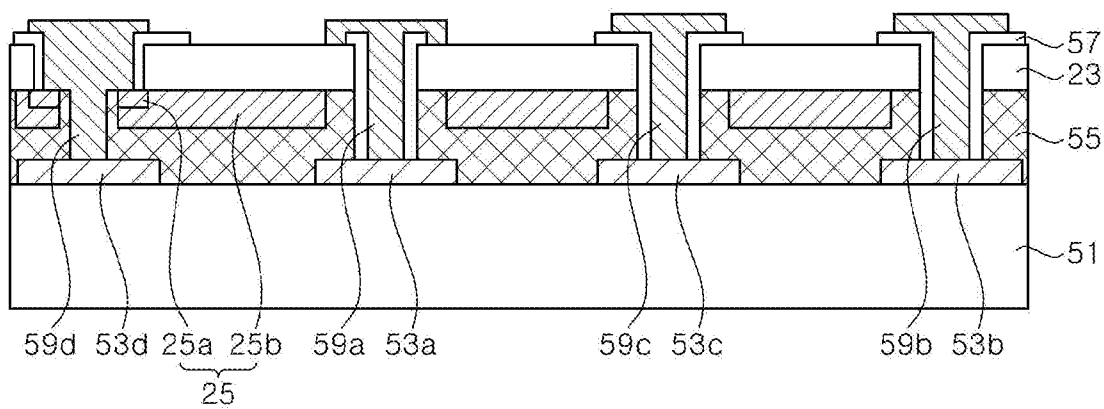


FIG. 11A

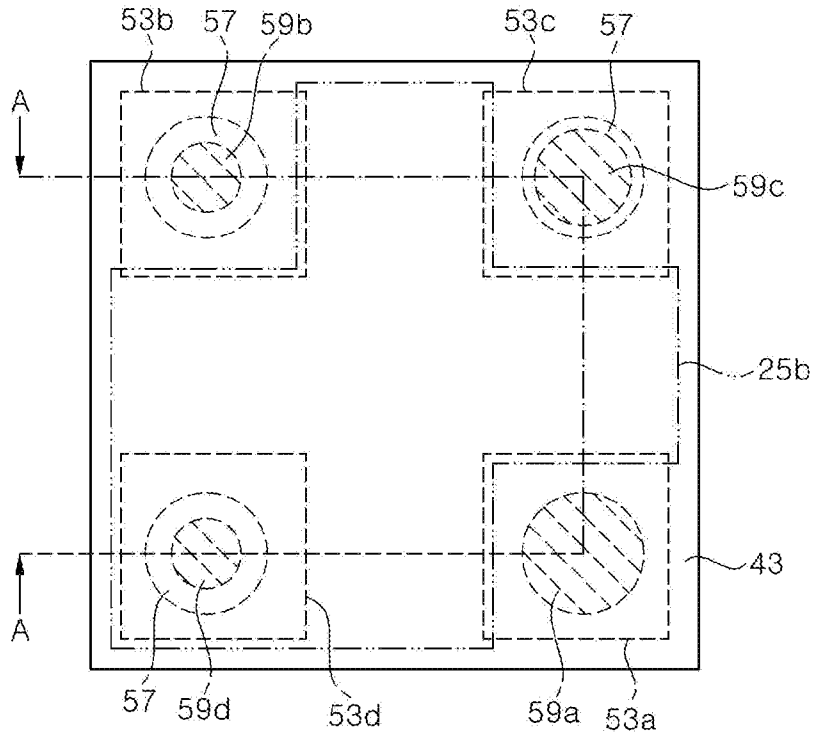


FIG. 11B

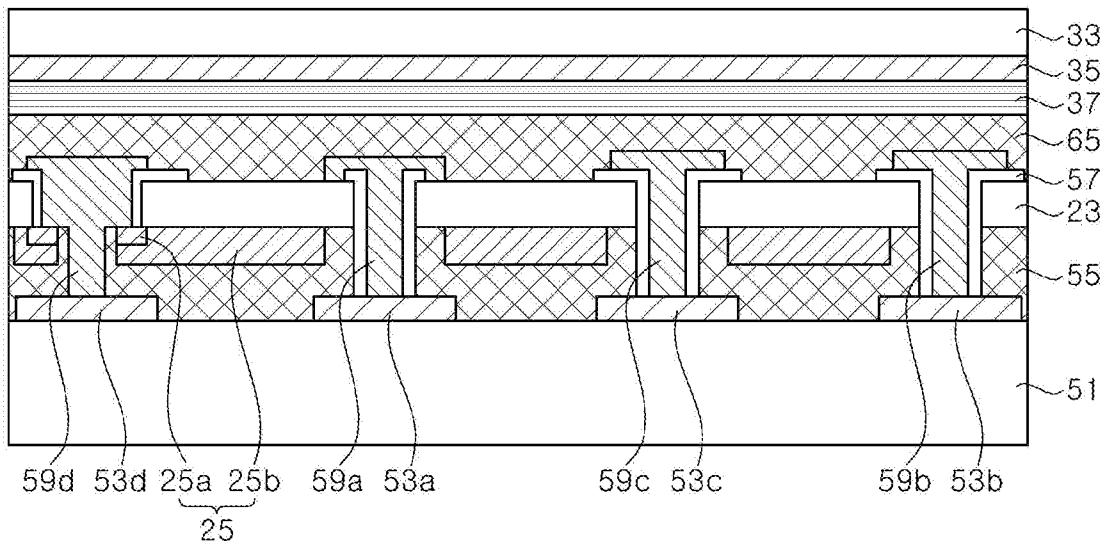


FIG. 12A

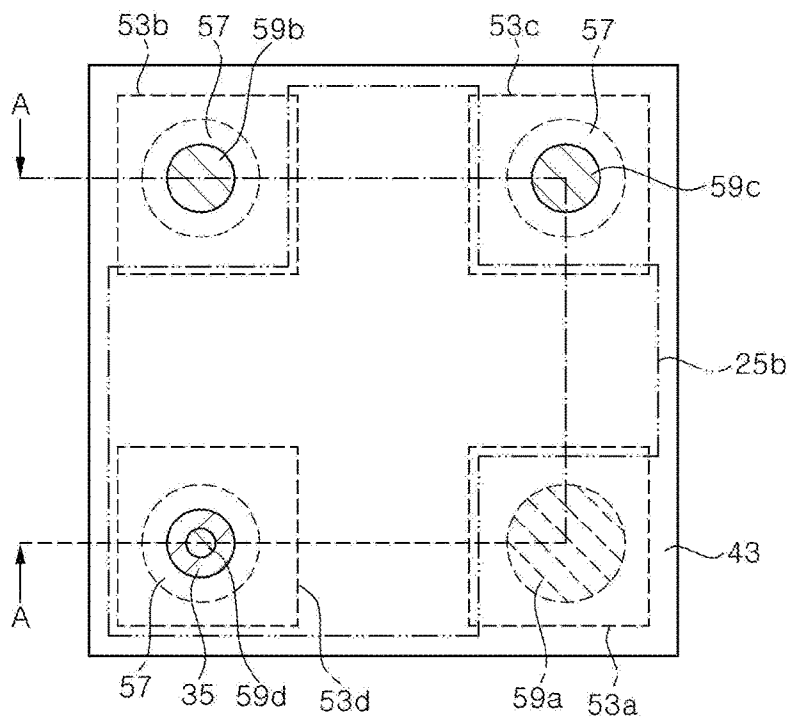


FIG. 12B

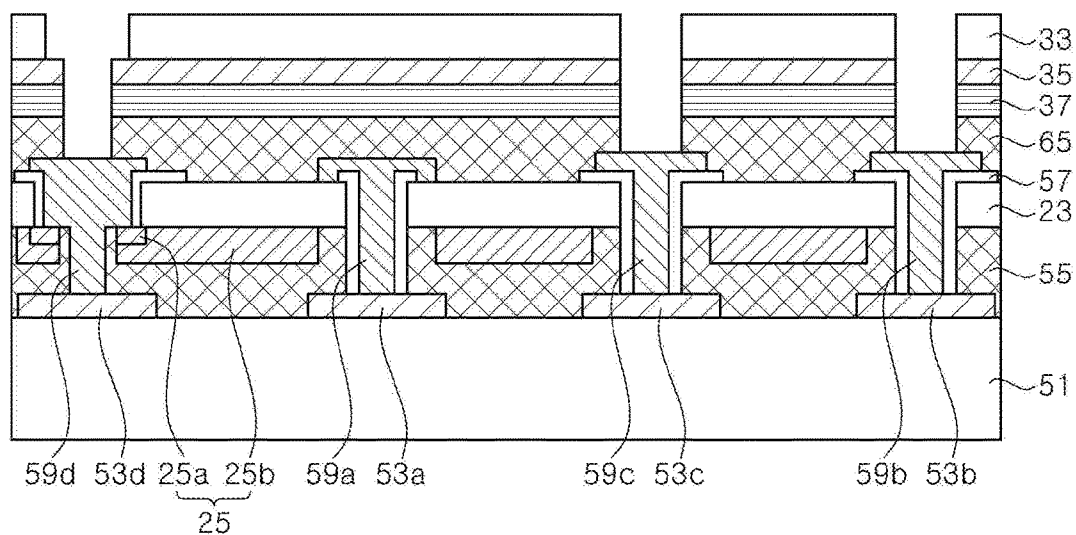


FIG. 13A

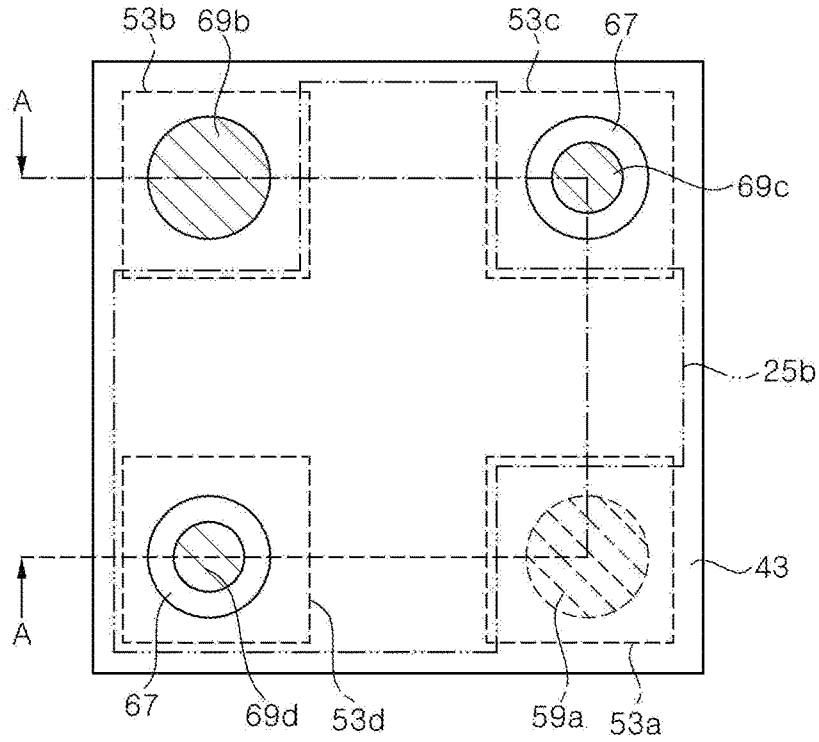


FIG. 13B

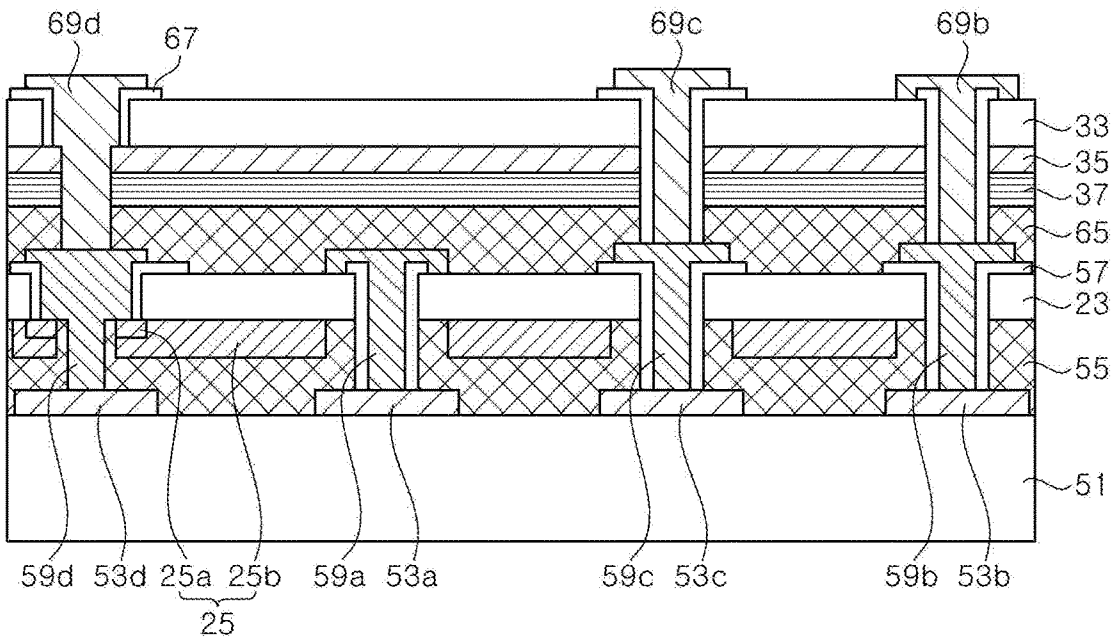


FIG. 14A

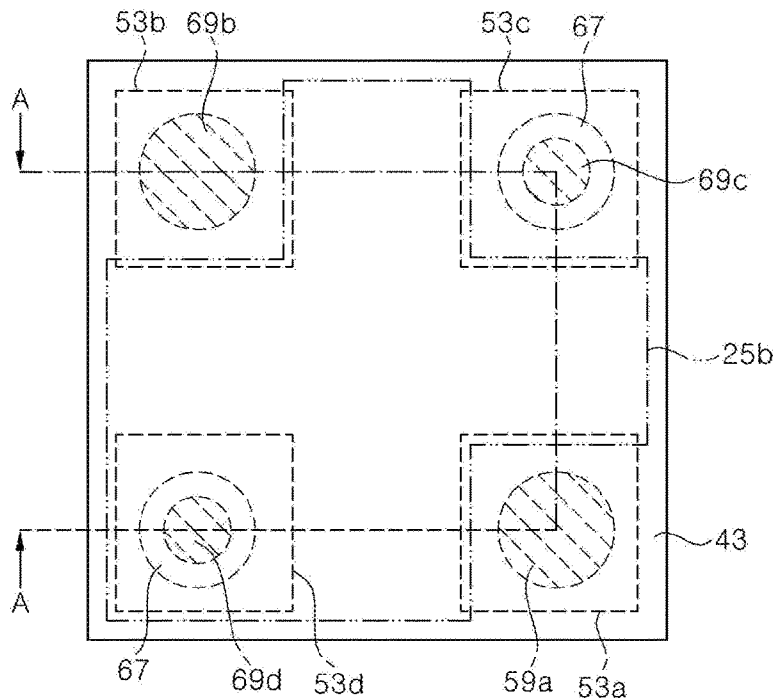


FIG. 14B

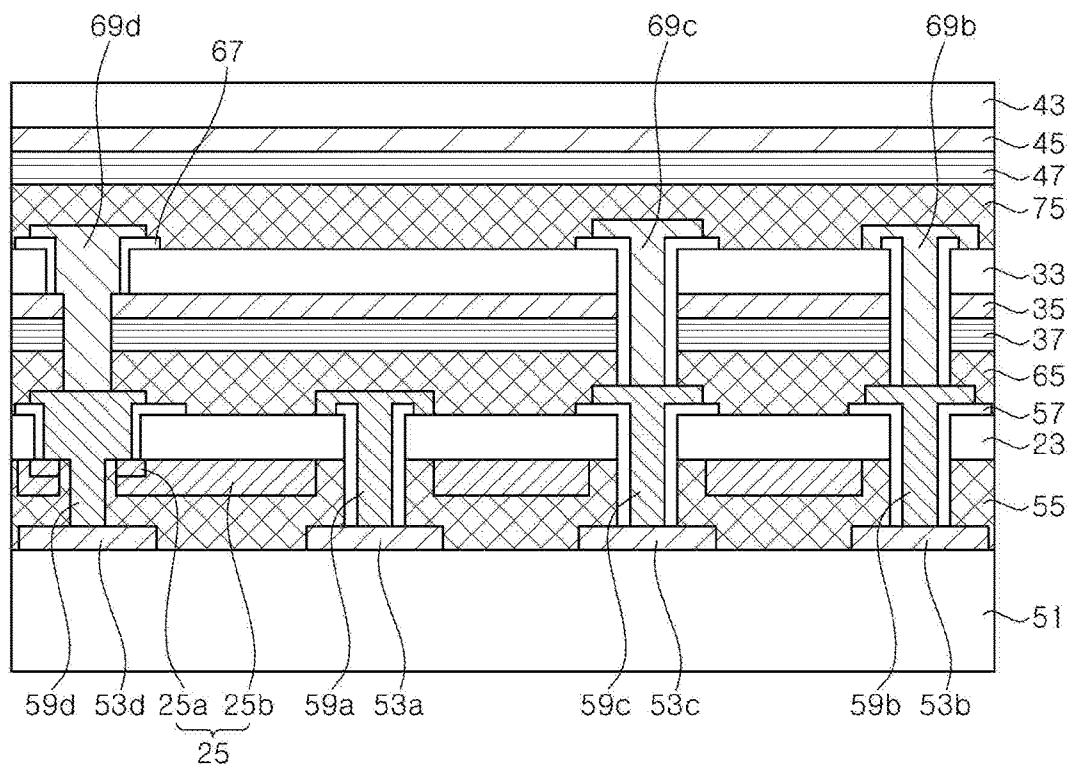


FIG. 15A

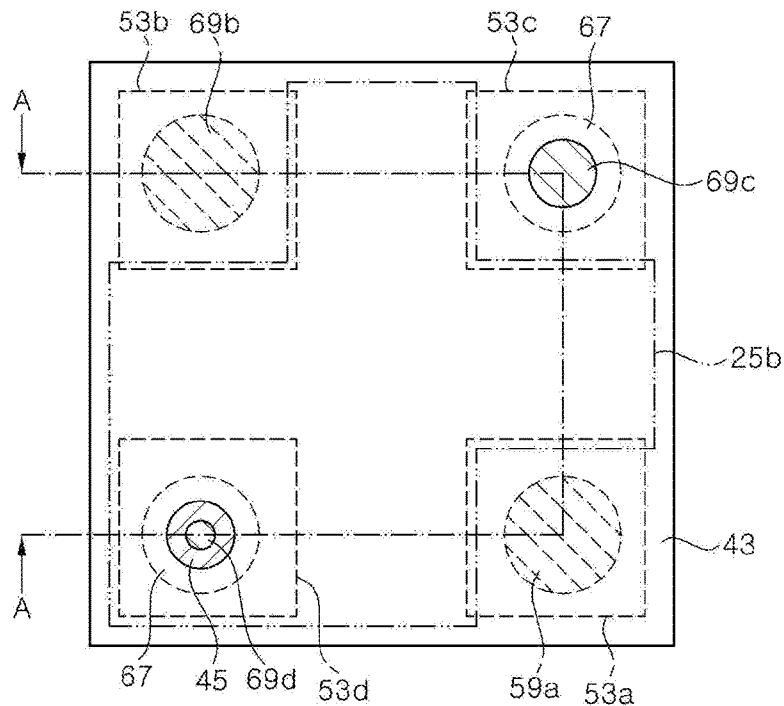


FIG. 15B

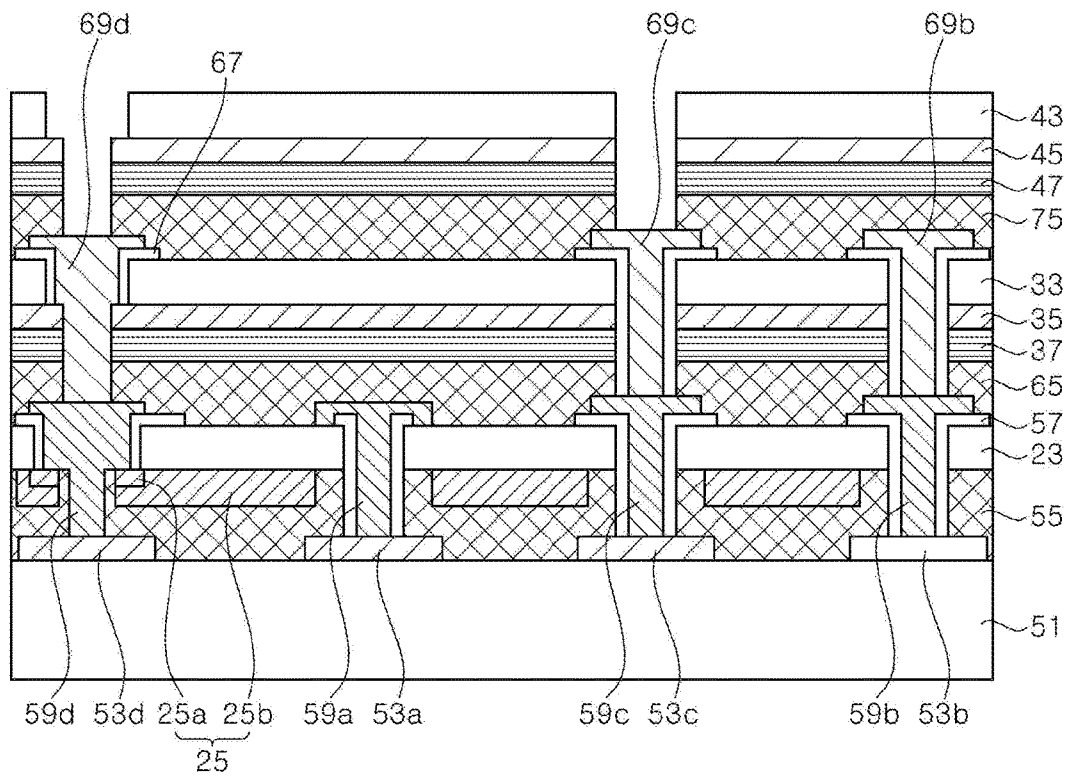


FIG. 16A

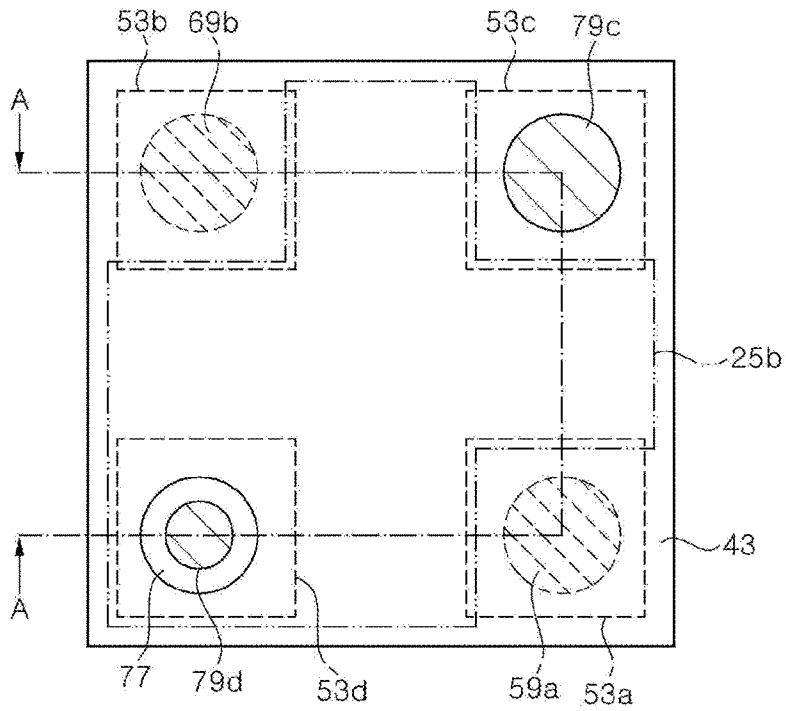


FIG. 16B

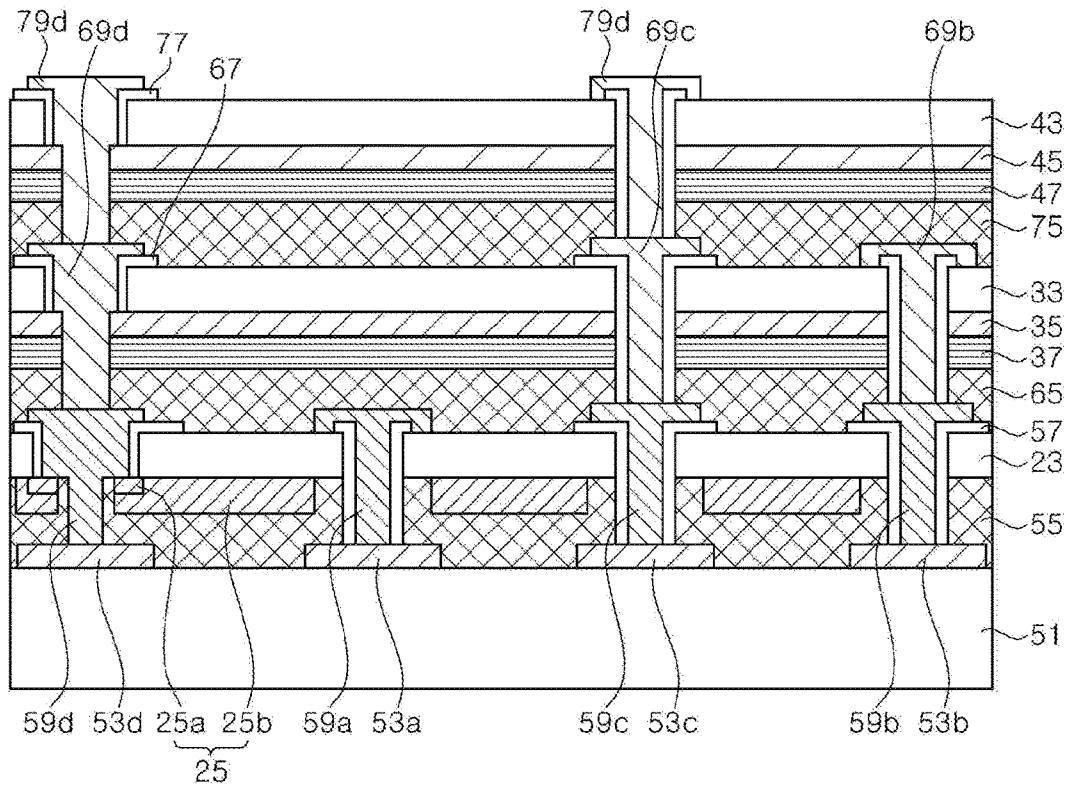


FIG. 17

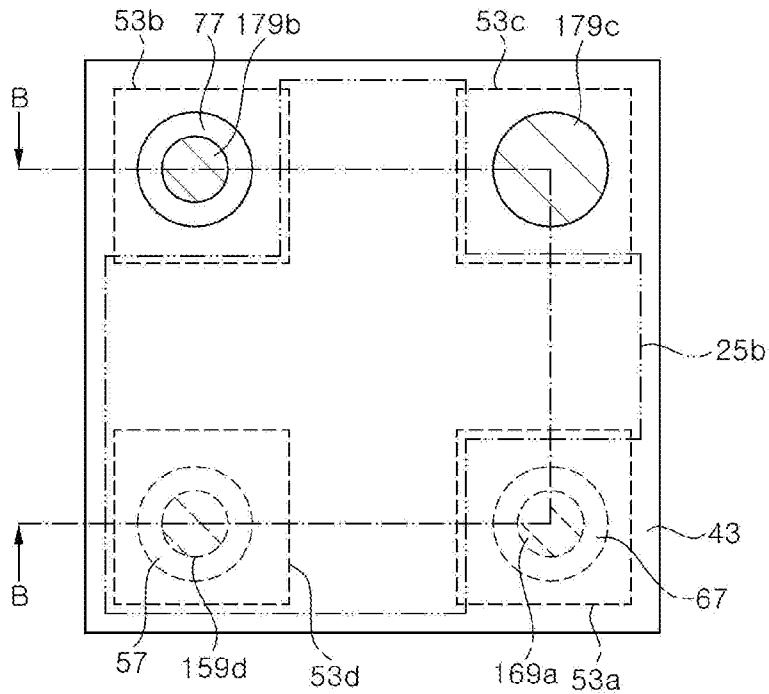


FIG. 18

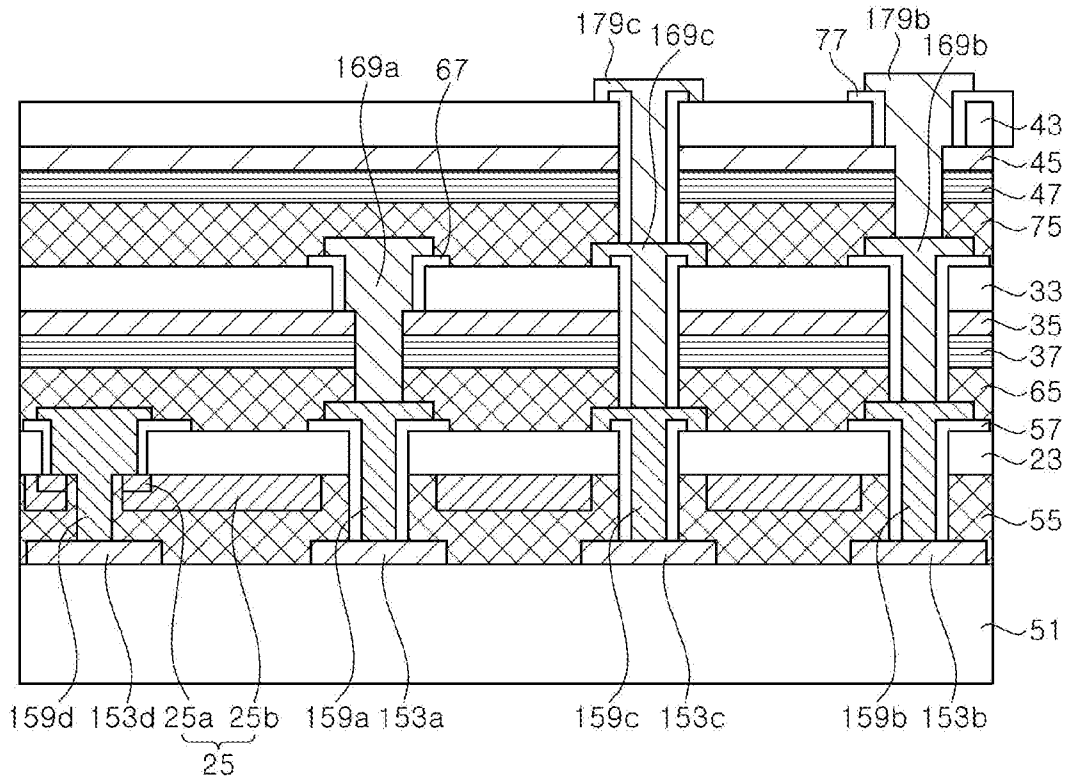


FIG. 19

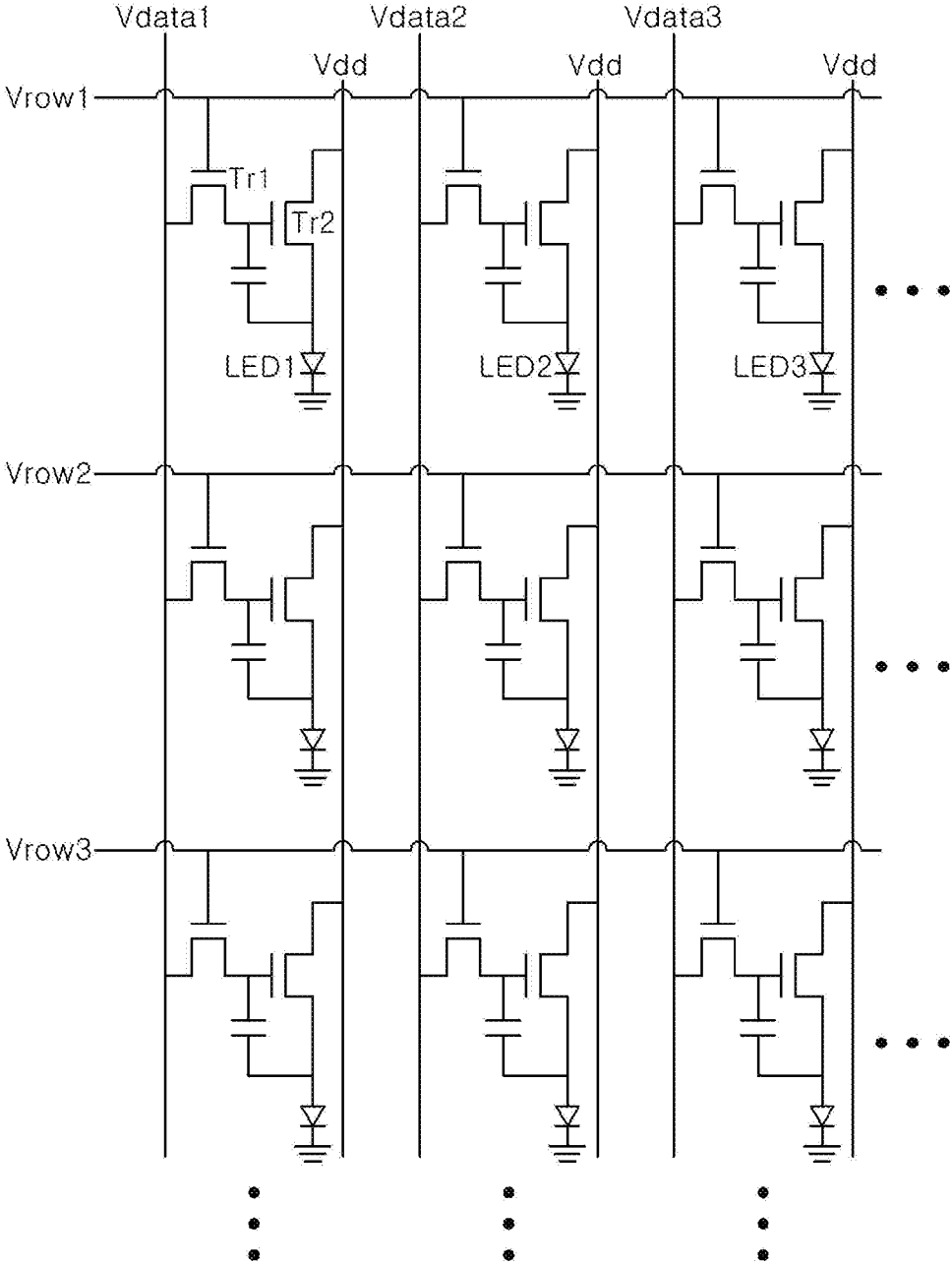


FIG. 20

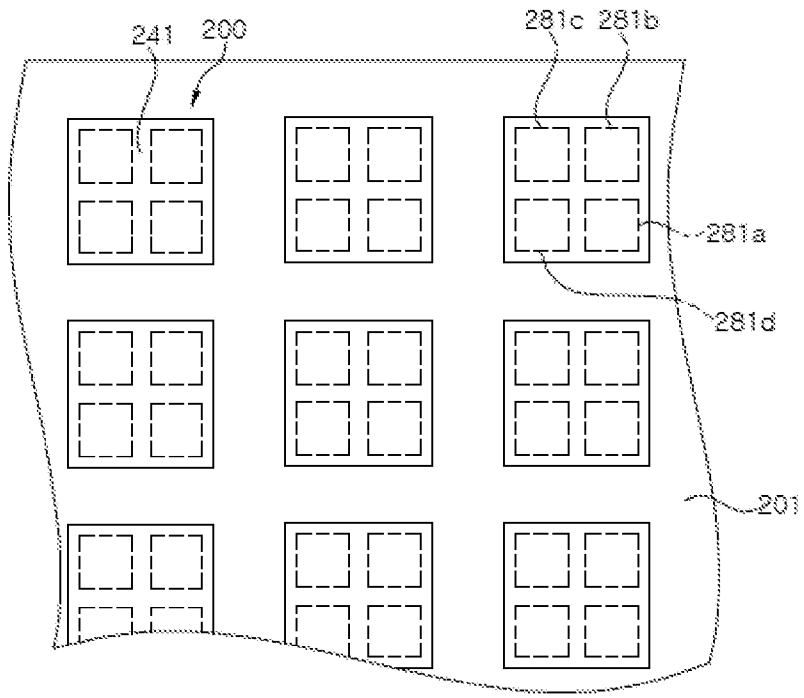


FIG. 21A

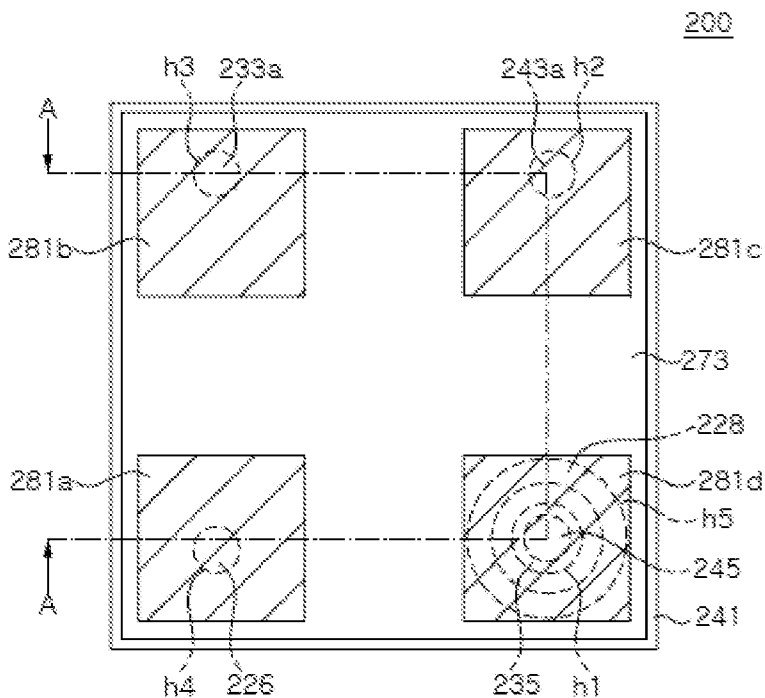


FIG. 21B

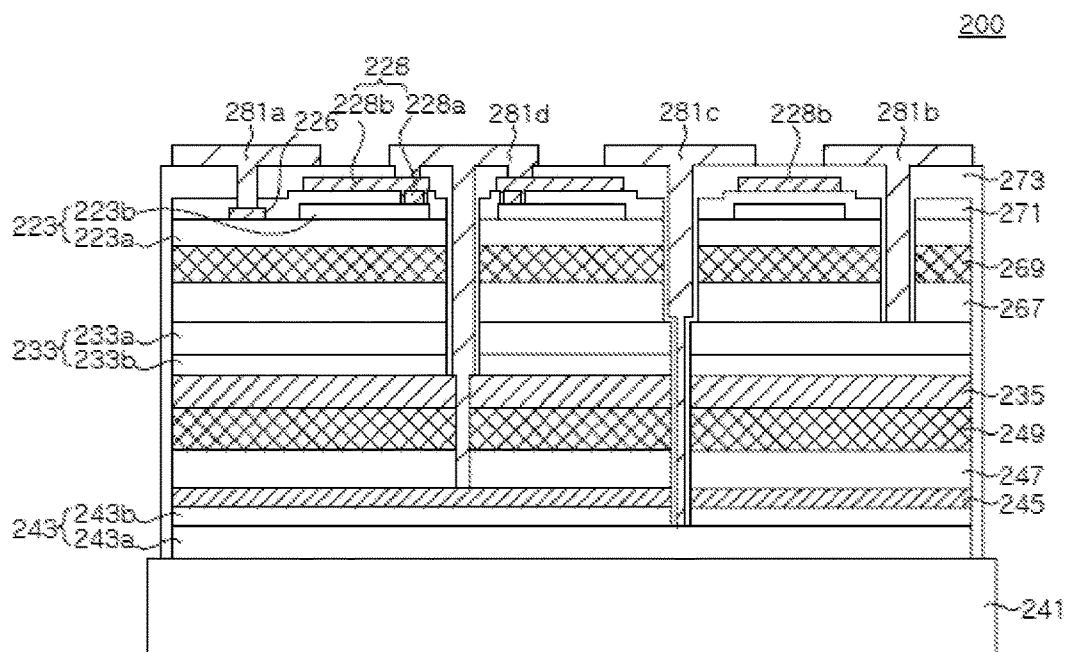


FIG. 22

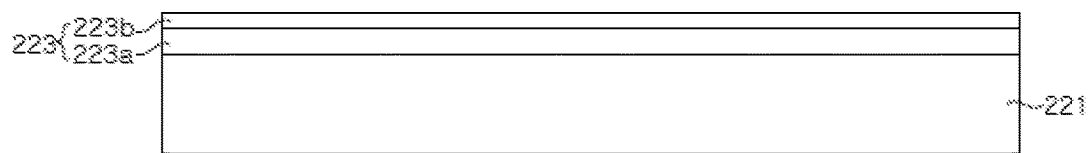


FIG. 23

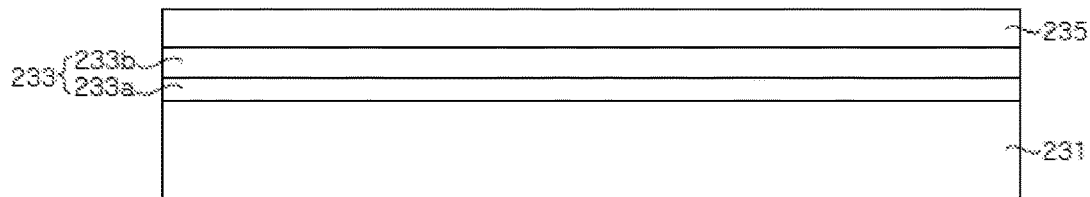


FIG. 24

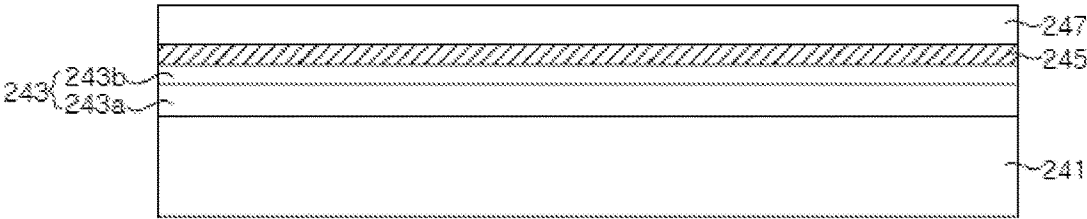


FIG. 25

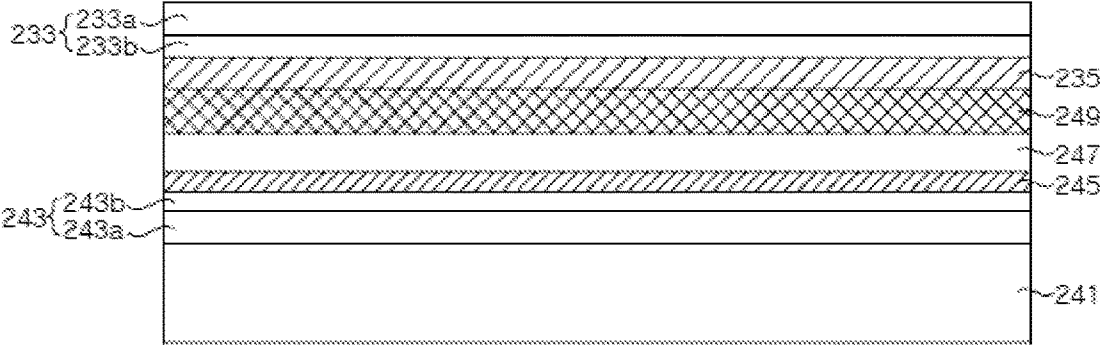


FIG. 26A

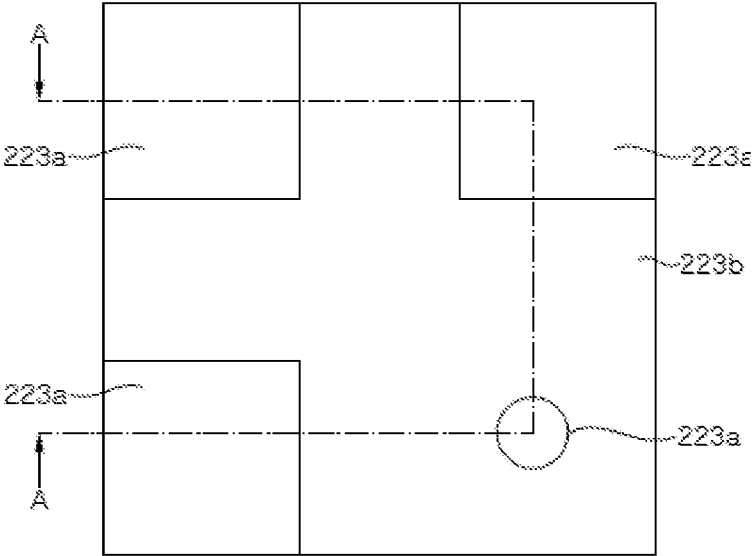


FIG. 26B

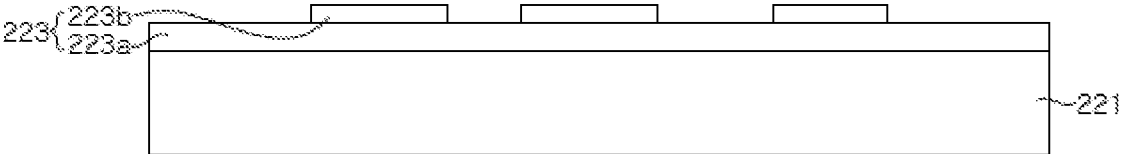


FIG. 27A

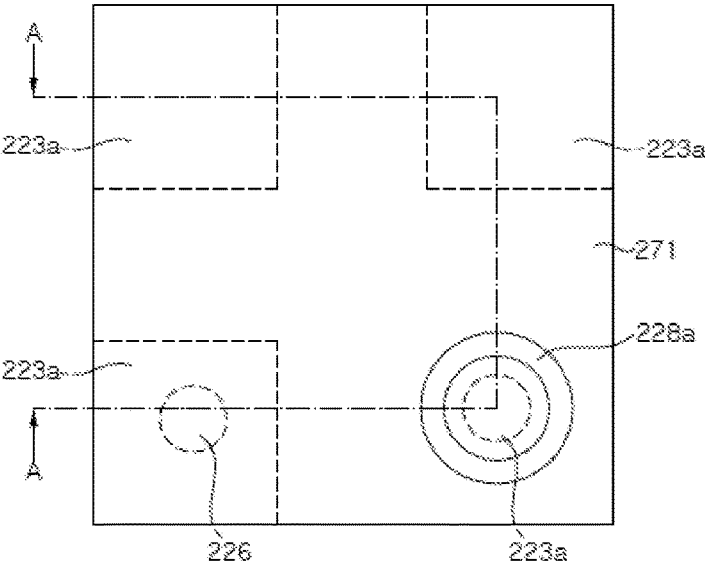


FIG. 27B

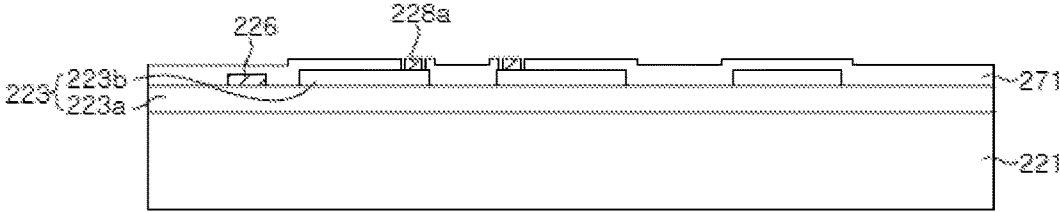


FIG. 28A

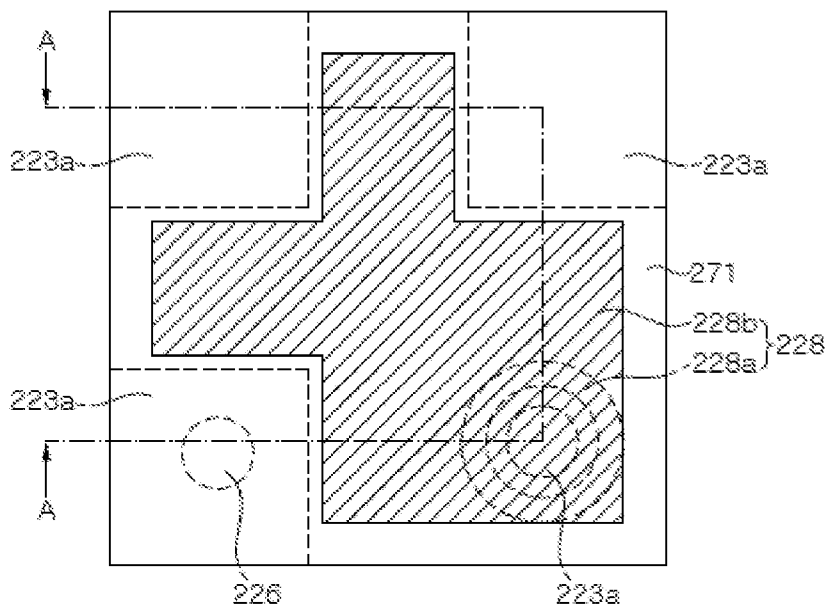


FIG. 28B

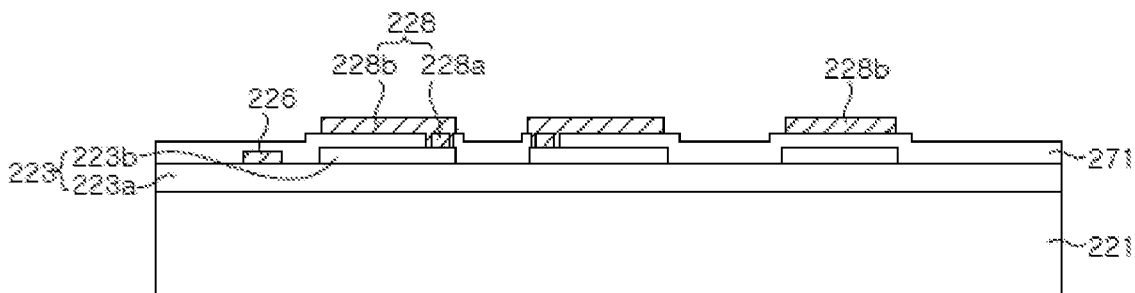


FIG. 29

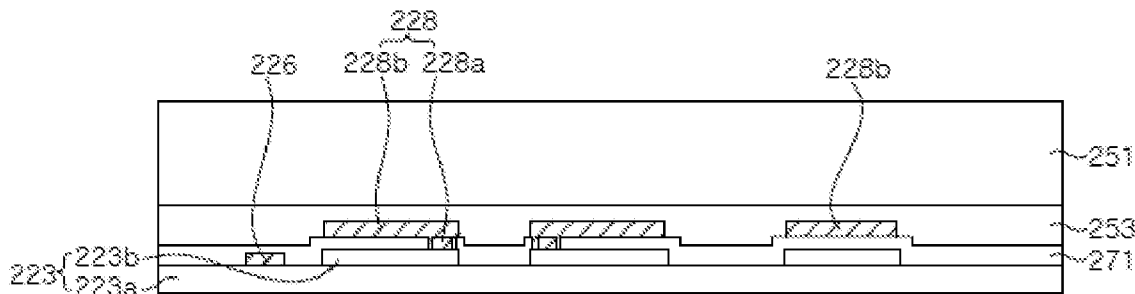


FIG. 30A

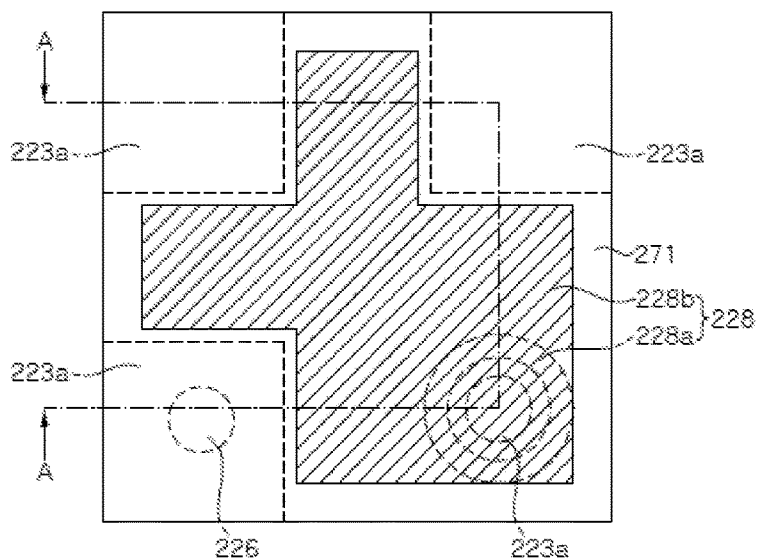


FIG. 30B

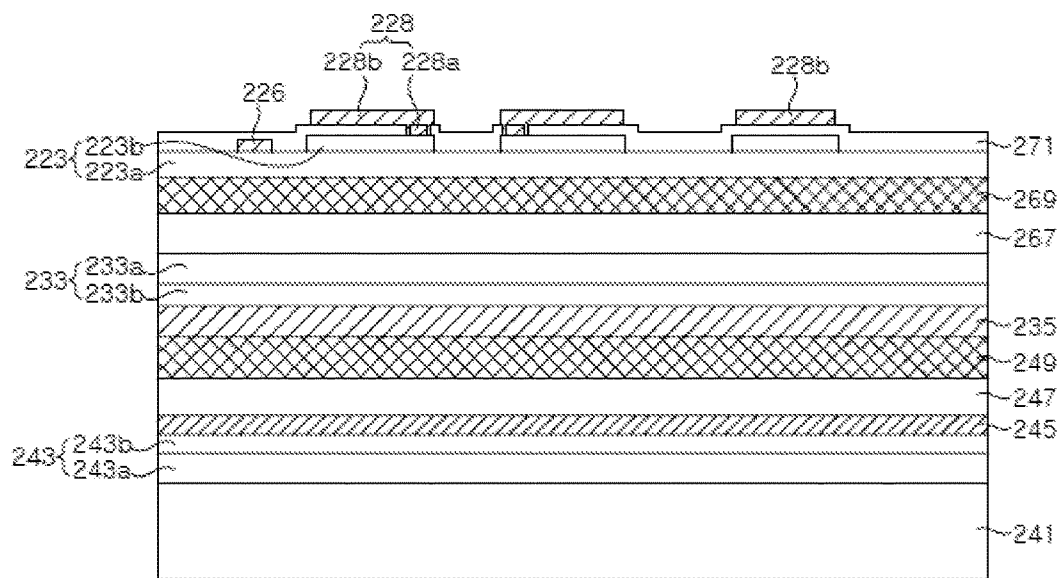


FIG. 31A

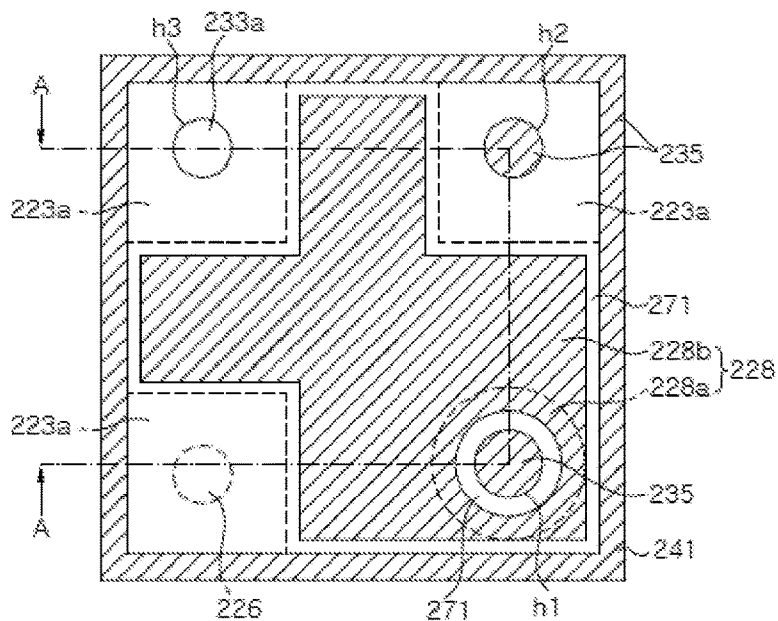


FIG. 31B

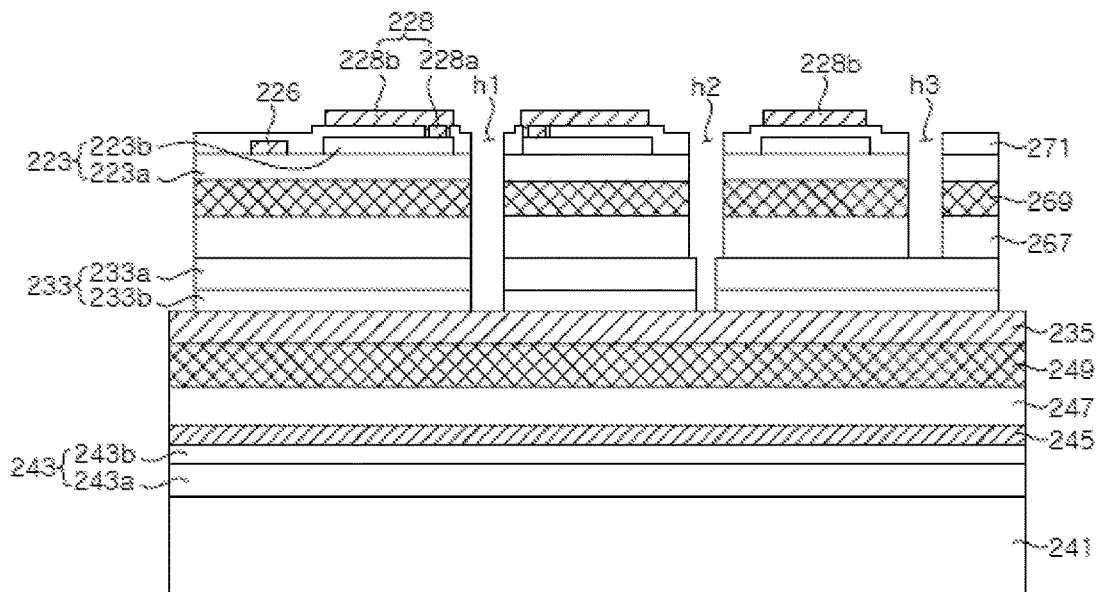


FIG. 32A

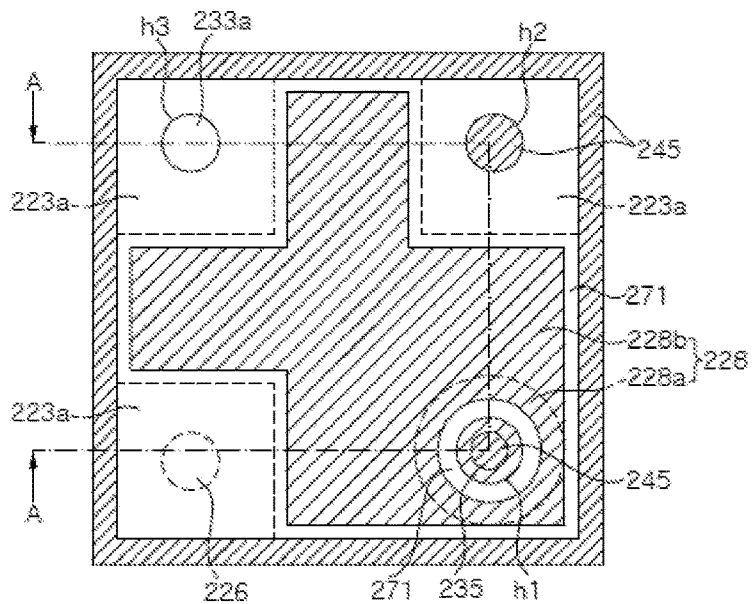


FIG. 32B

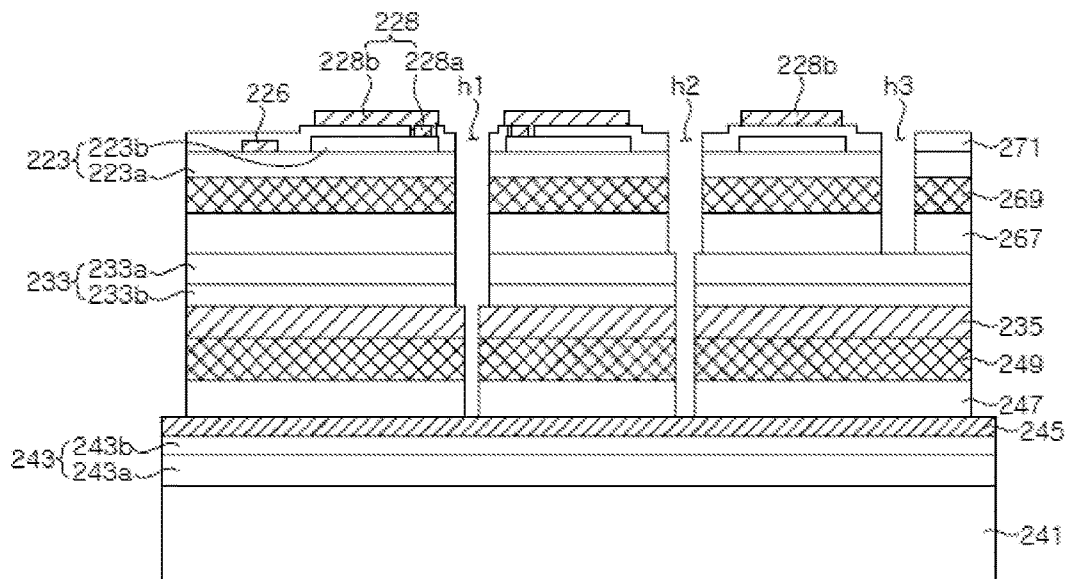


FIG. 33A

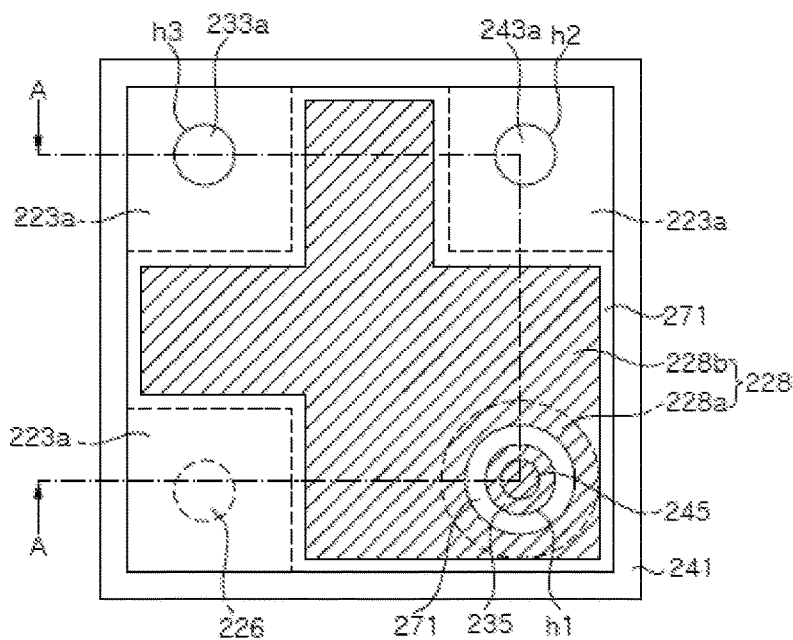


FIG. 33B

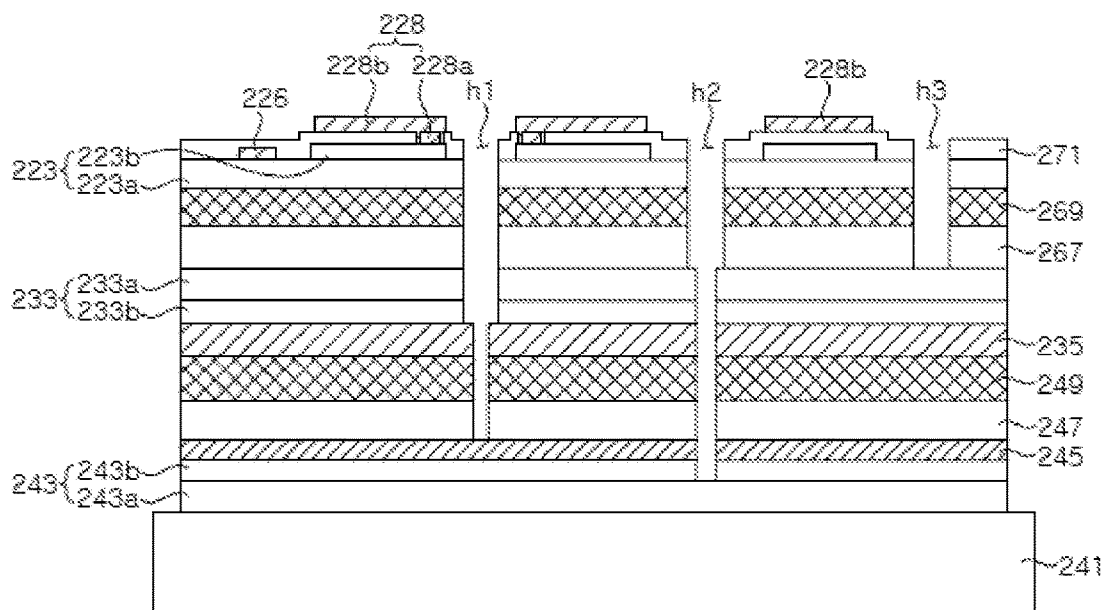


FIG. 34A

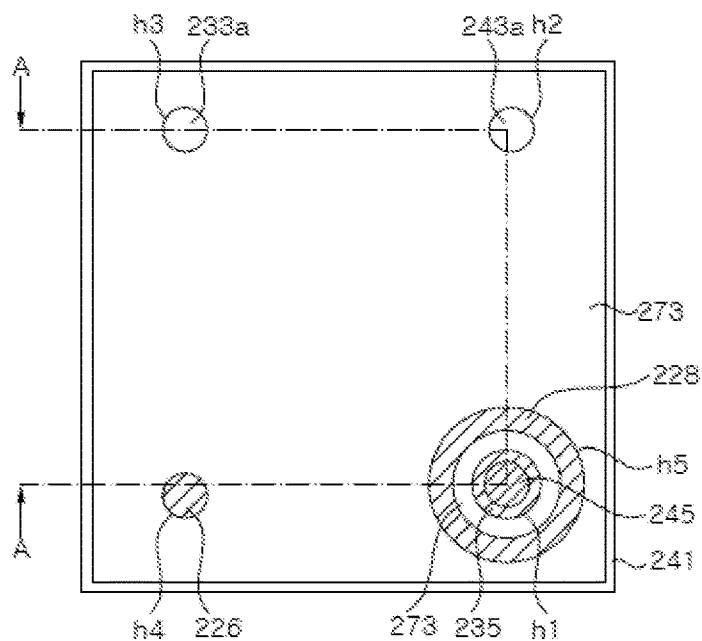


FIG. 34B

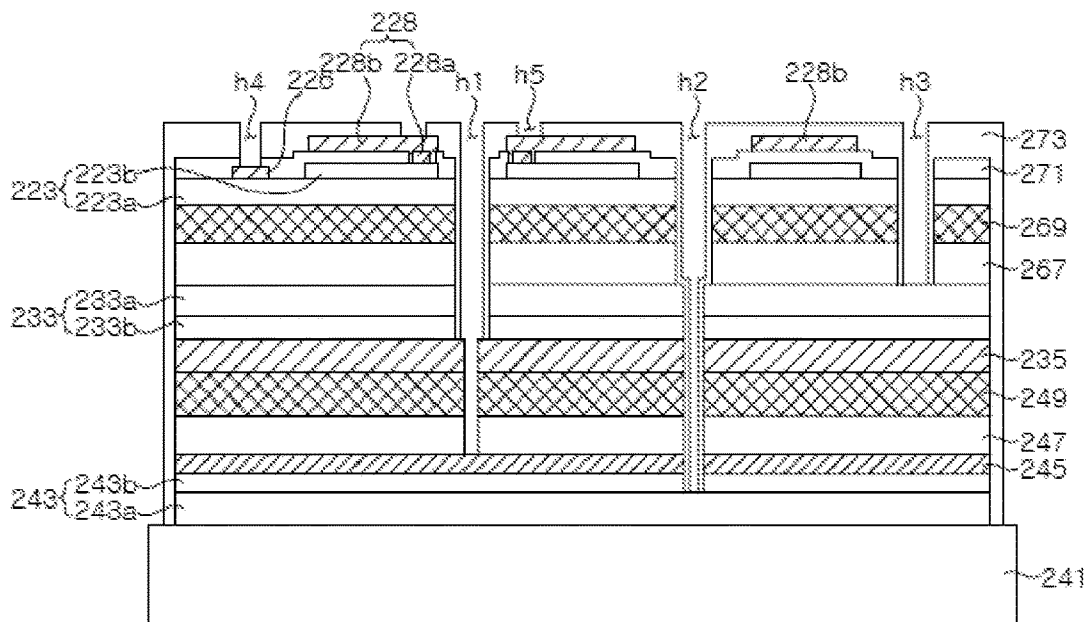


FIG. 35A

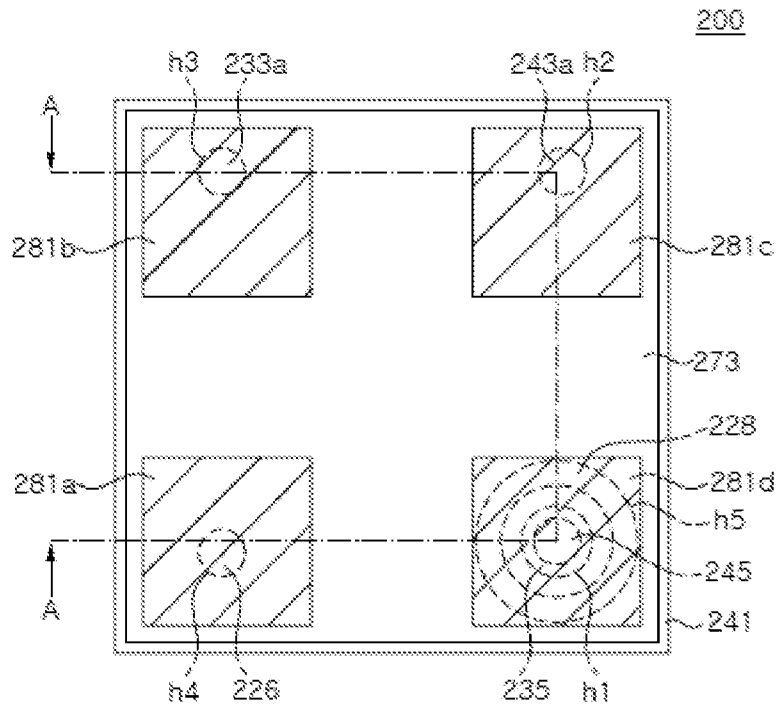


FIG. 35B

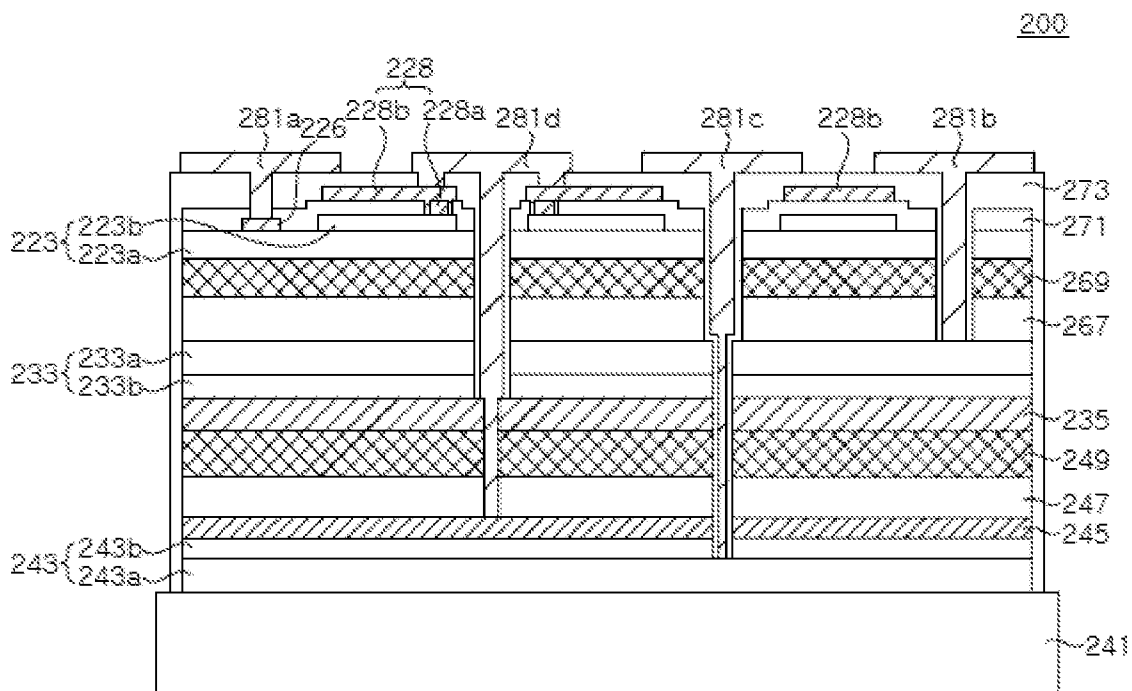


FIG. 36

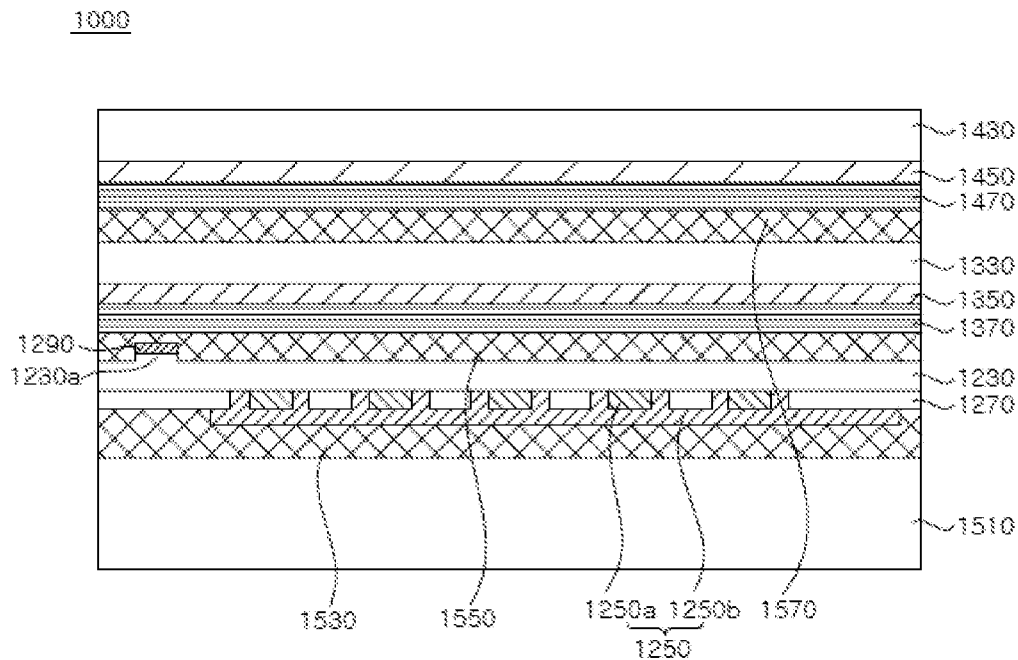


FIG. 37A

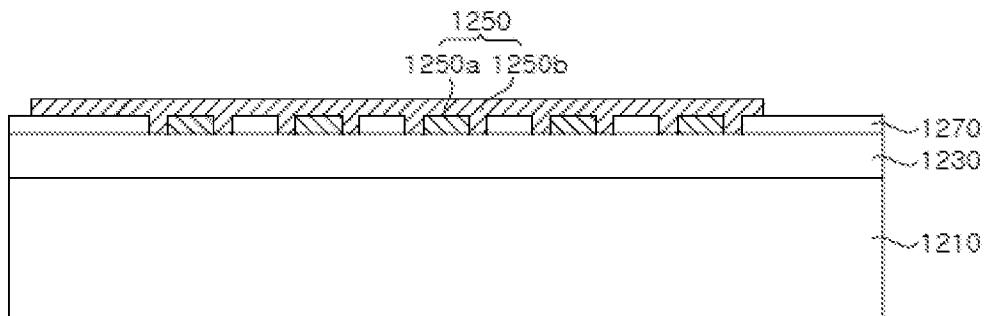


FIG. 37B

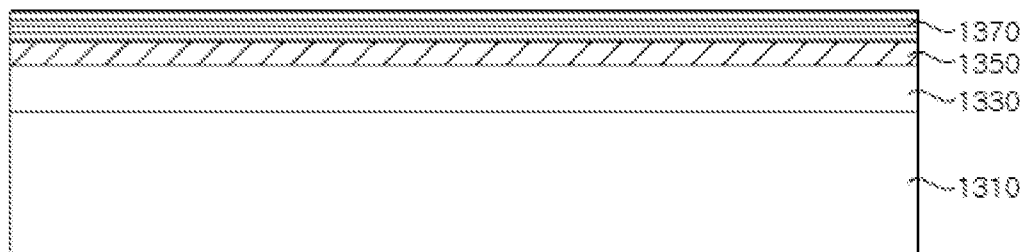


FIG. 37C

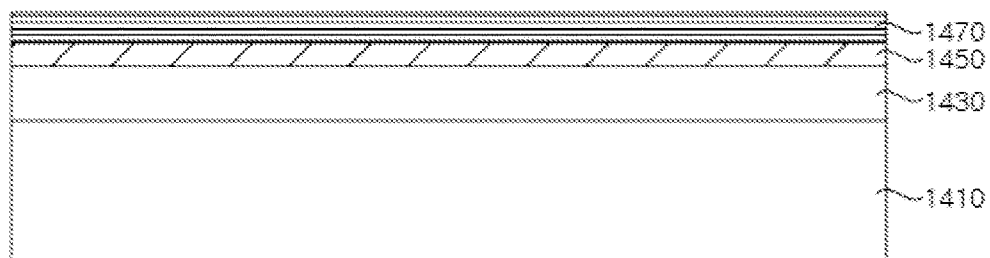


FIG. 37D

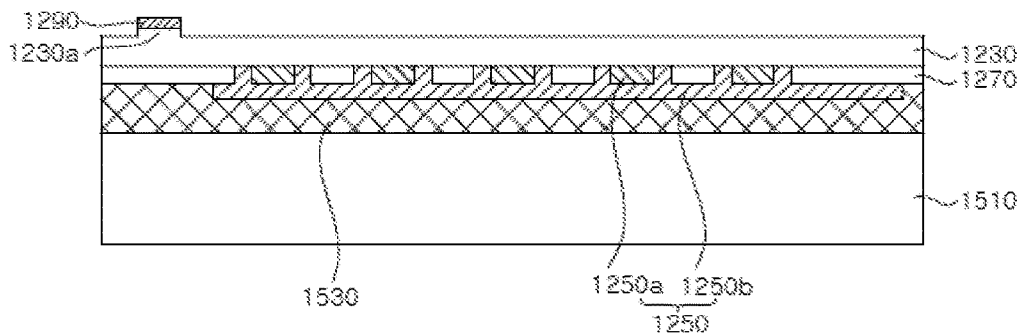


FIG. 37E

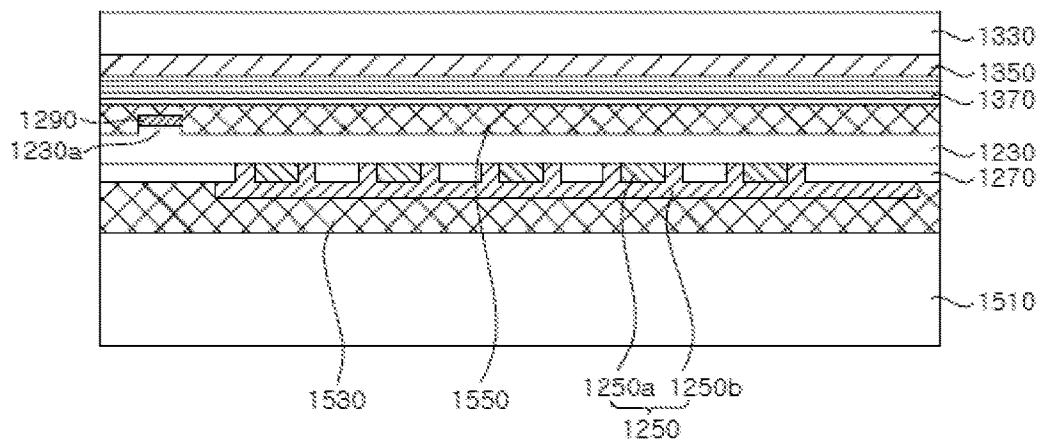


FIG. 38

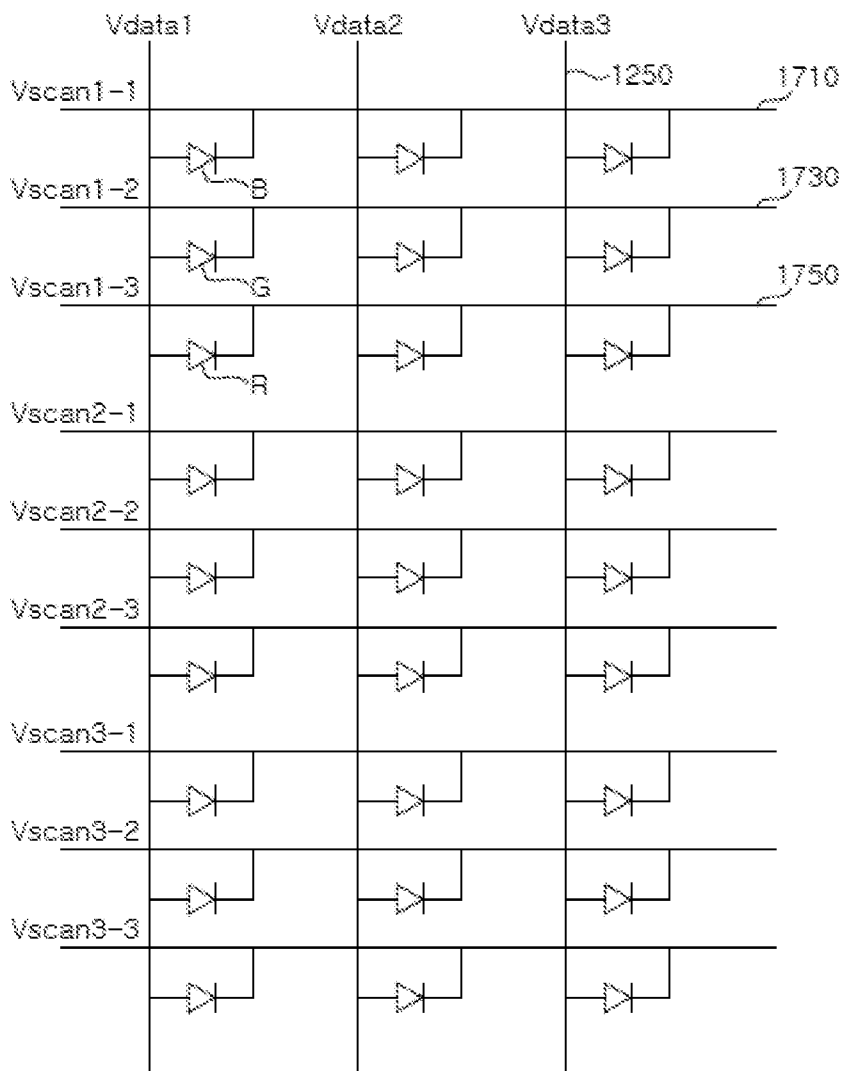


FIG. 39

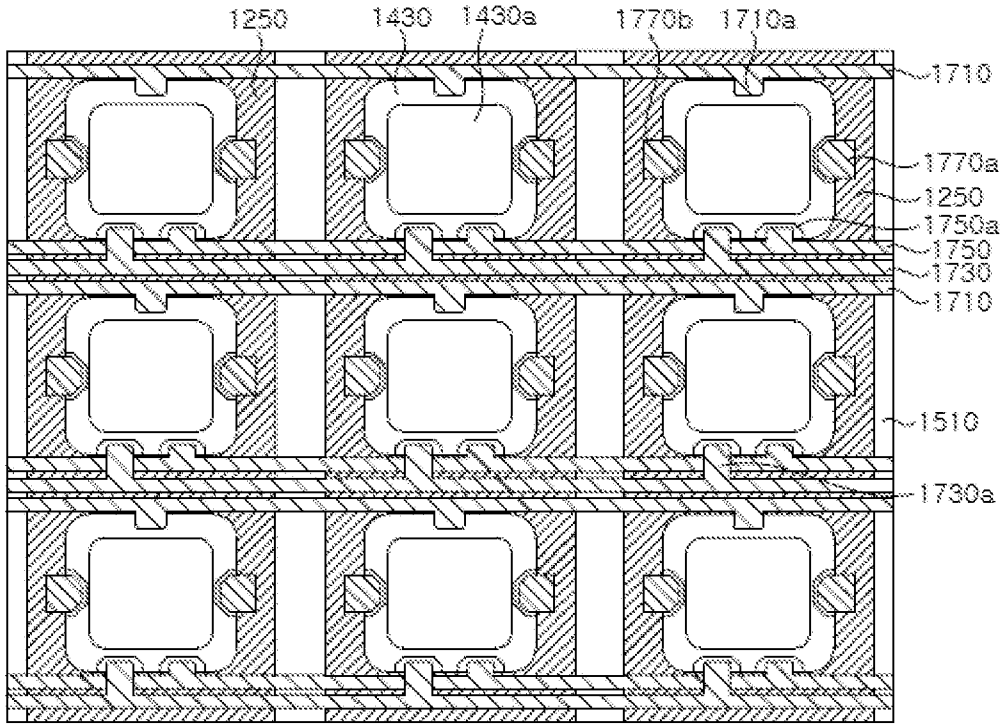


FIG. 40

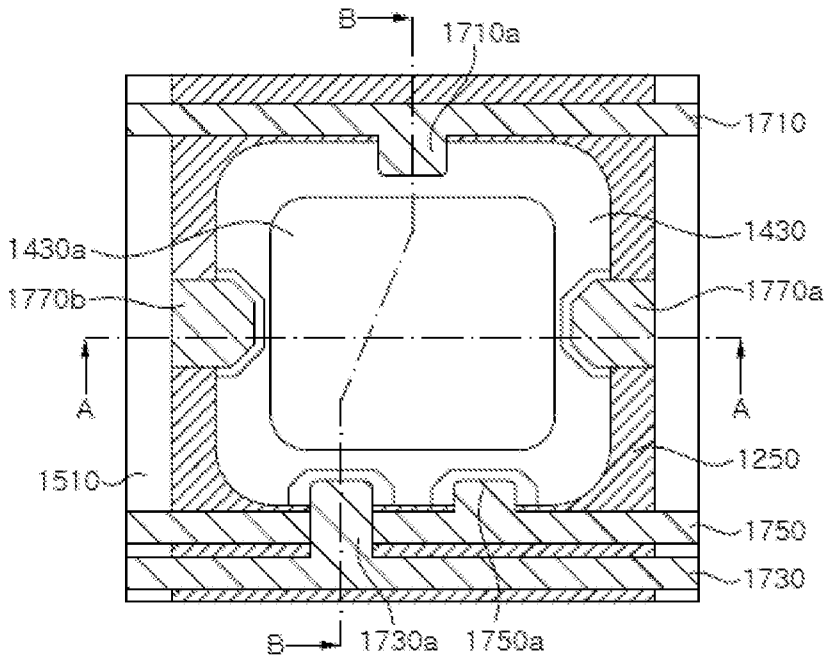


FIG. 41

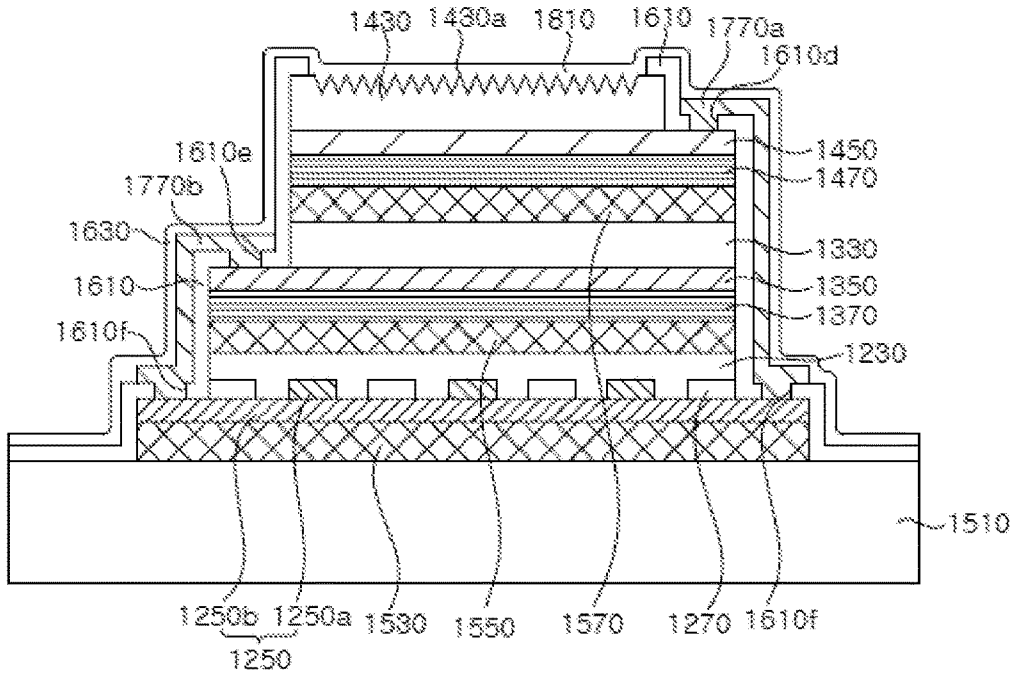


FIG. 42

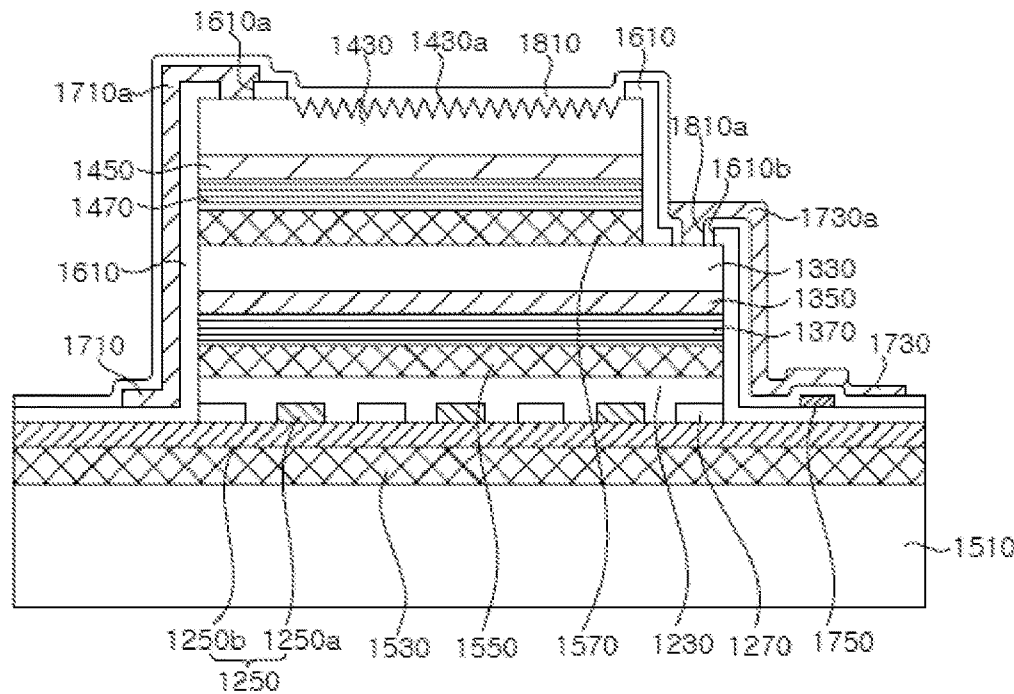


FIG. 43A

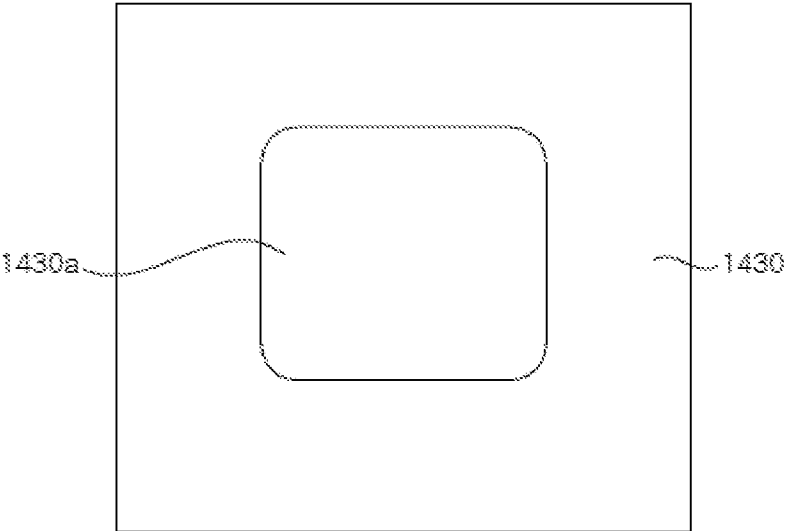


FIG. 43B

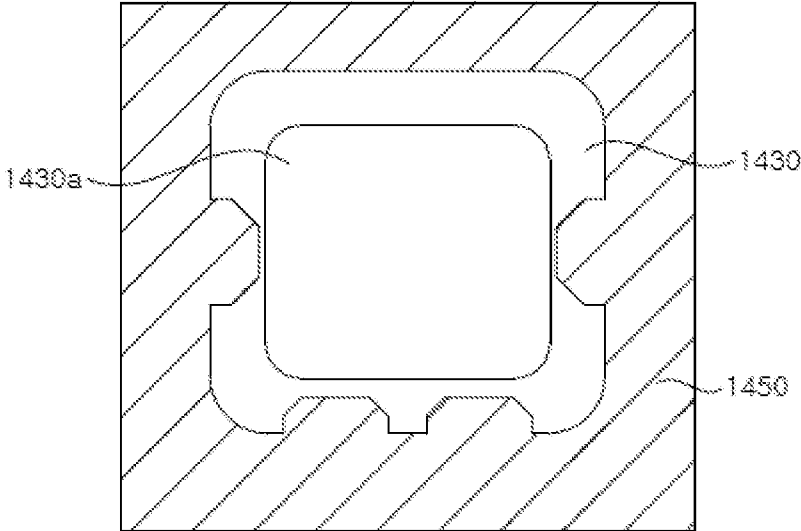


FIG. 43C

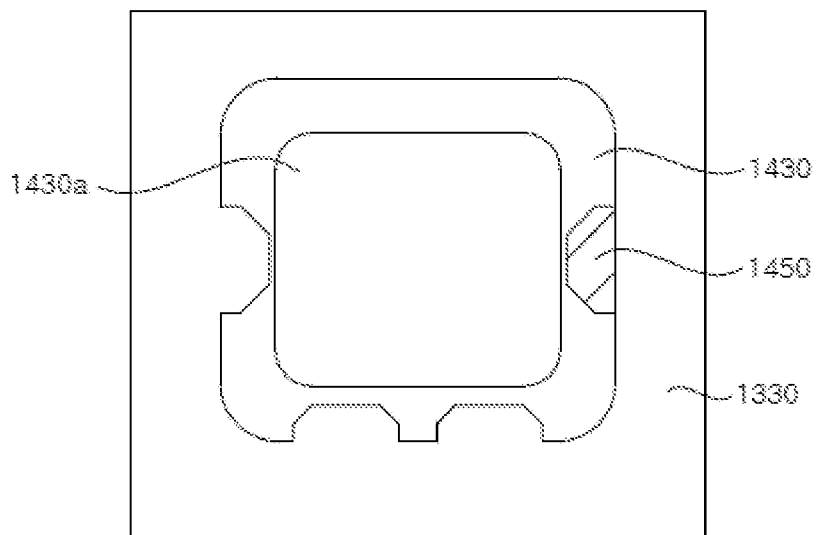


FIG. 43D

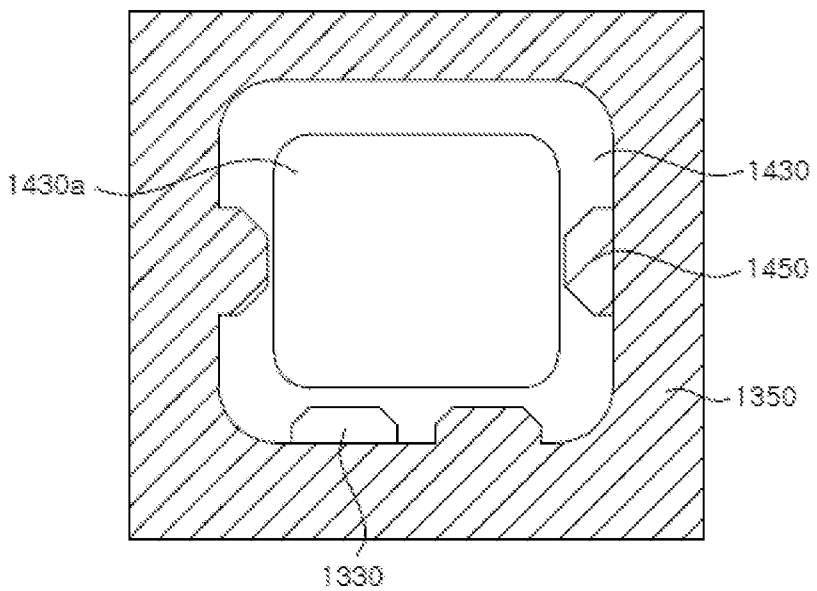


FIG. 43E

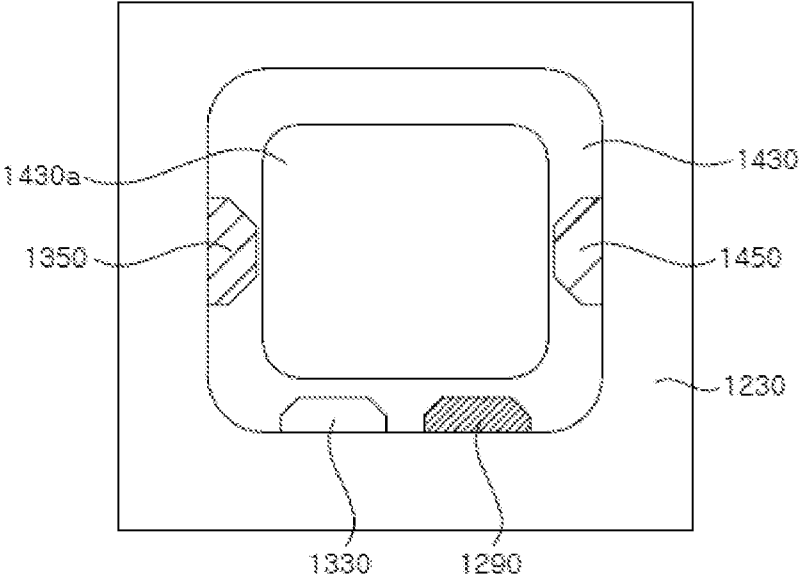


FIG. 43F

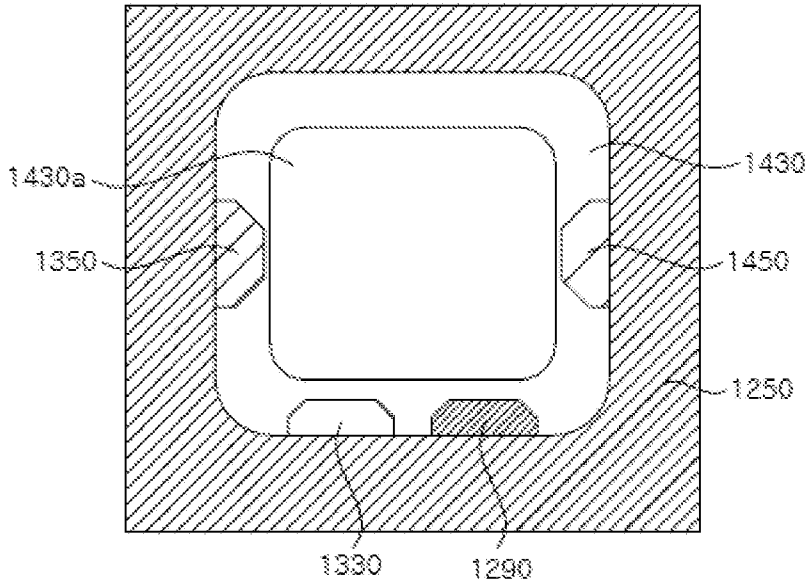


FIG. 43G

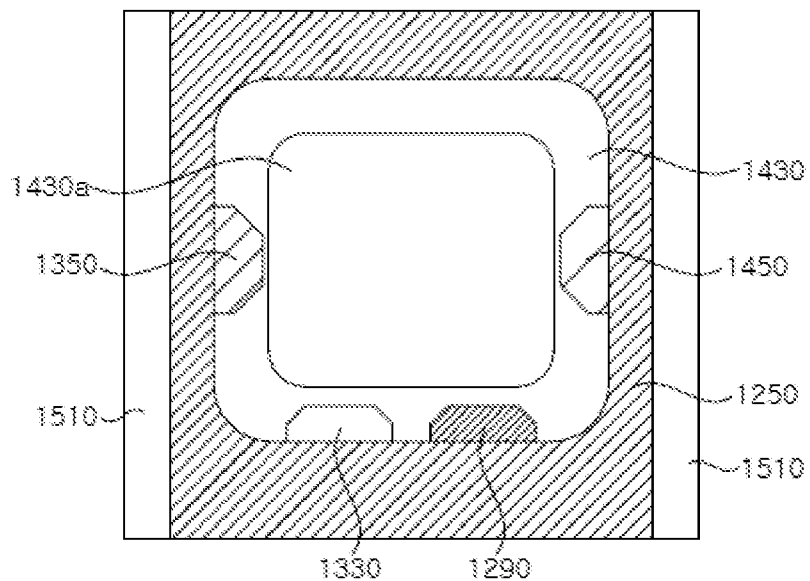


FIG. 43H

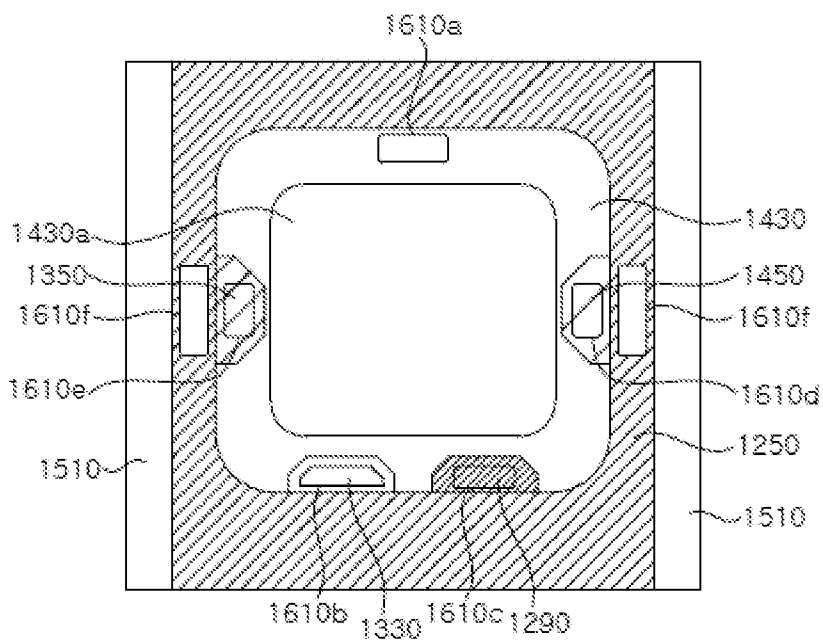


FIG. 43I

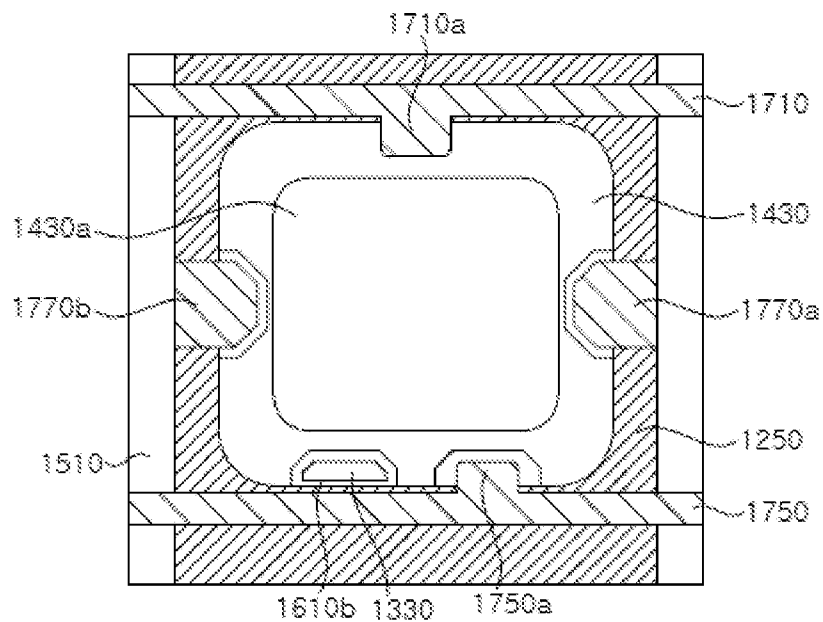


FIG. 43J

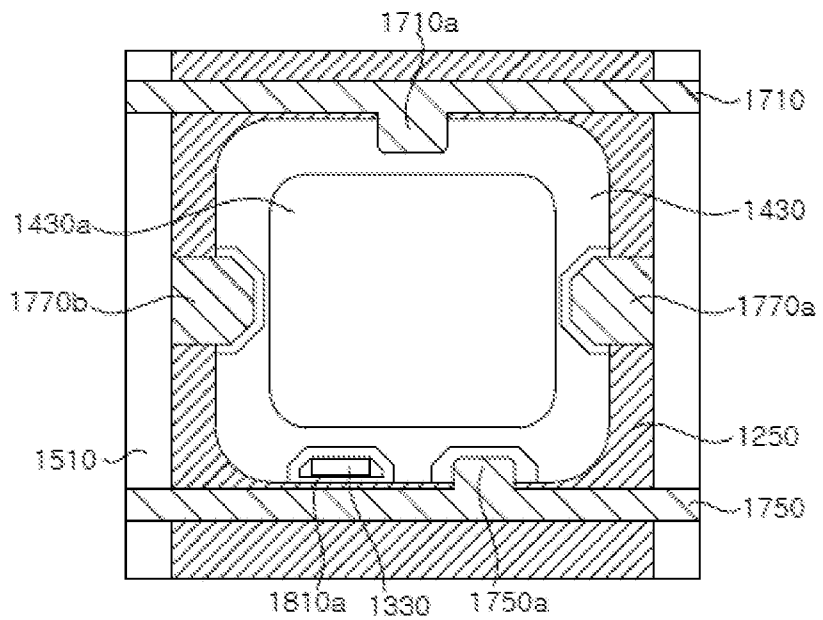


FIG. 43K

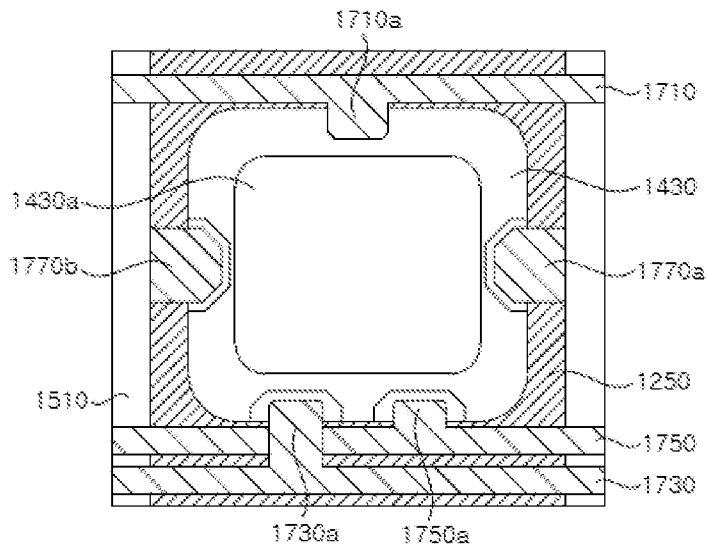


FIG. 44

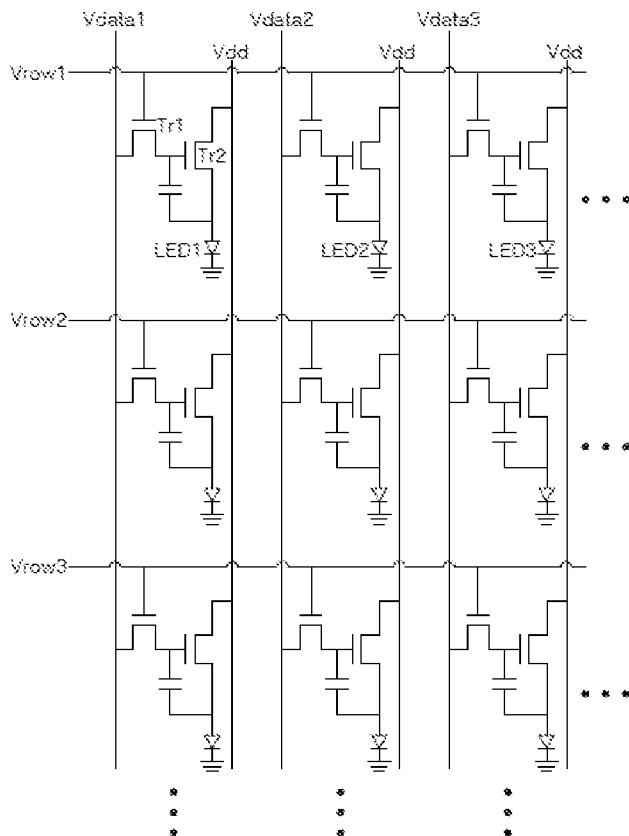


FIG. 45

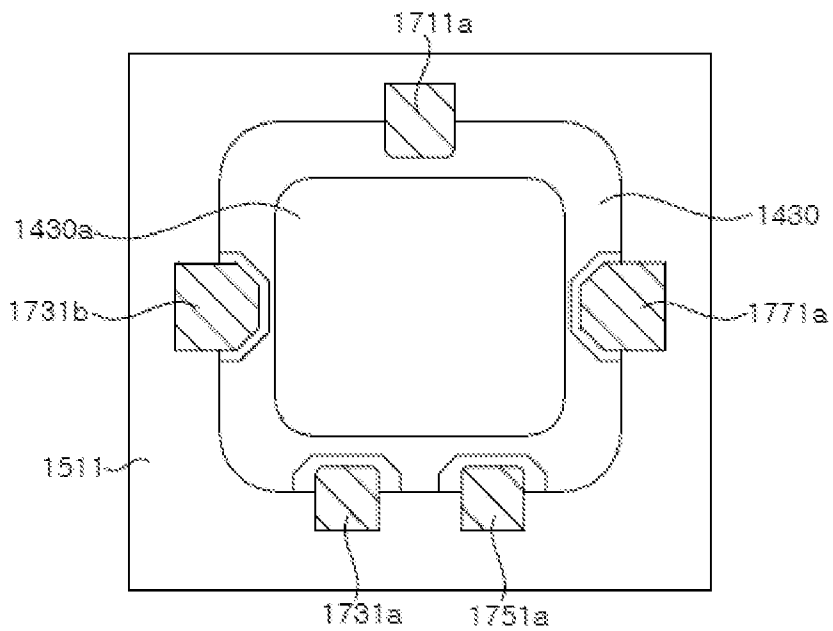


FIG. 46

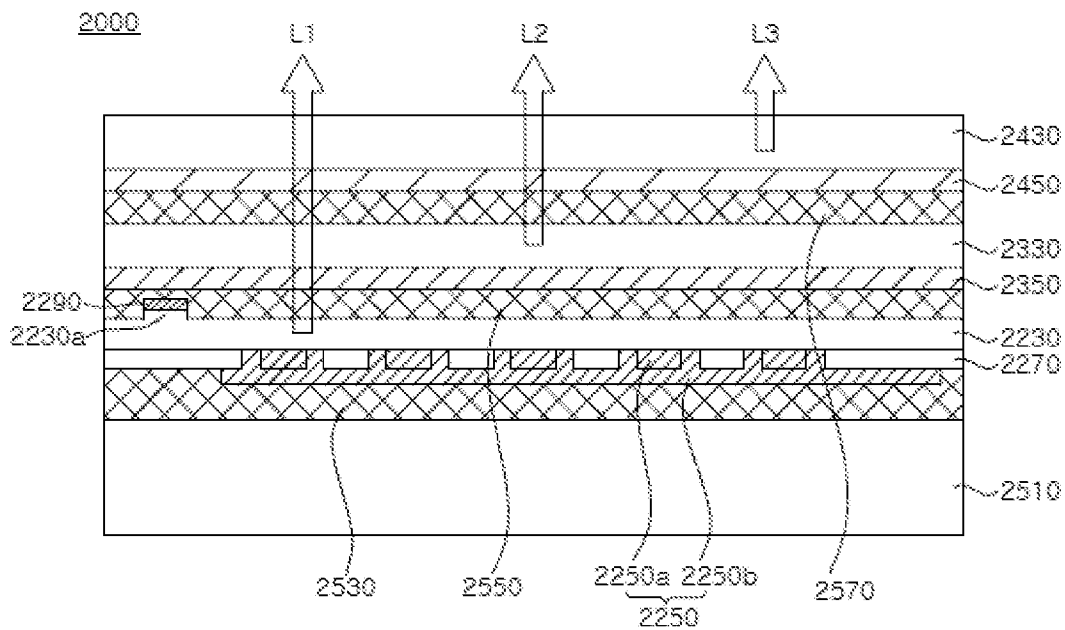


FIG. 47A

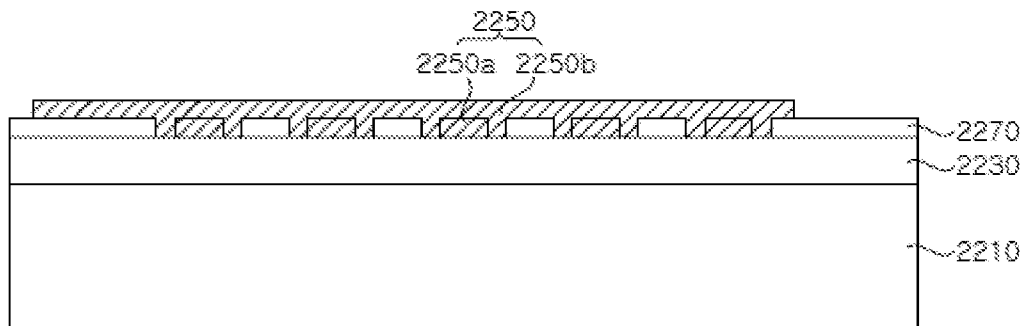


FIG. 47B

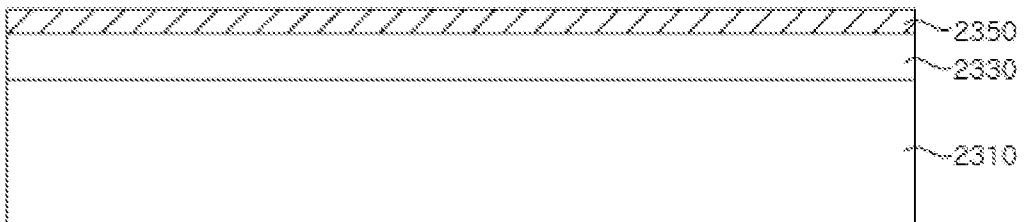


FIG. 47C

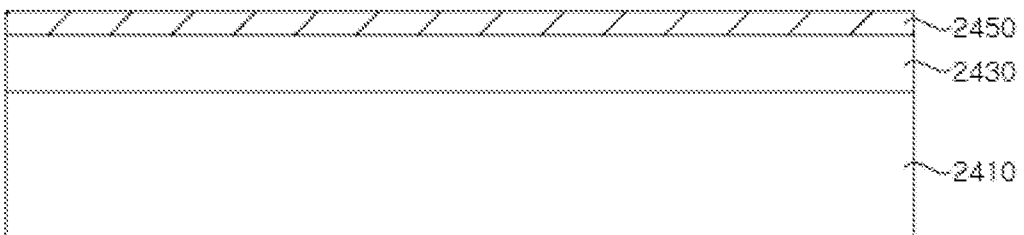


FIG. 47D

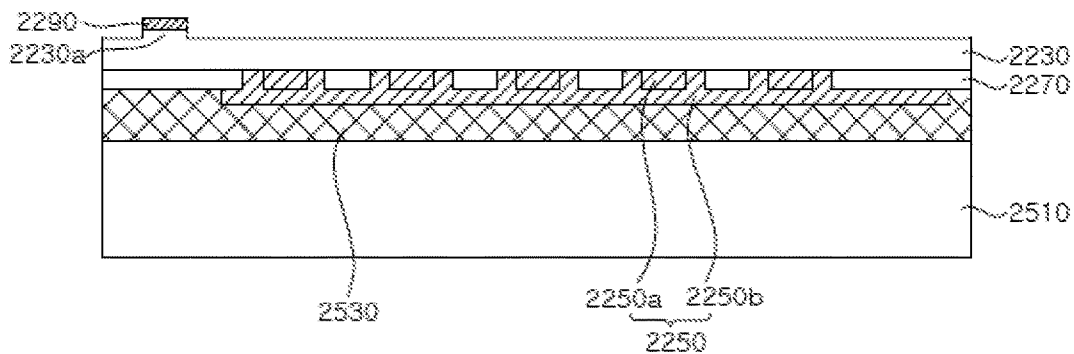


FIG. 47E

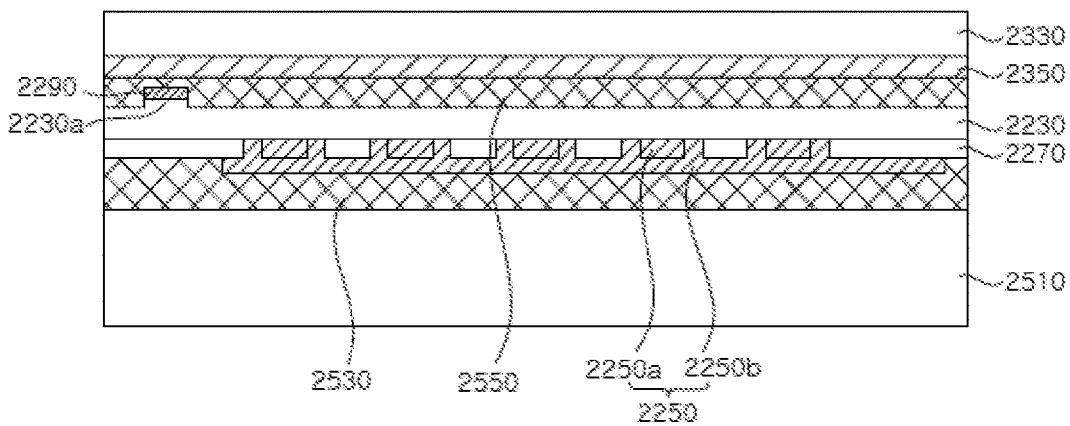


FIG. 48

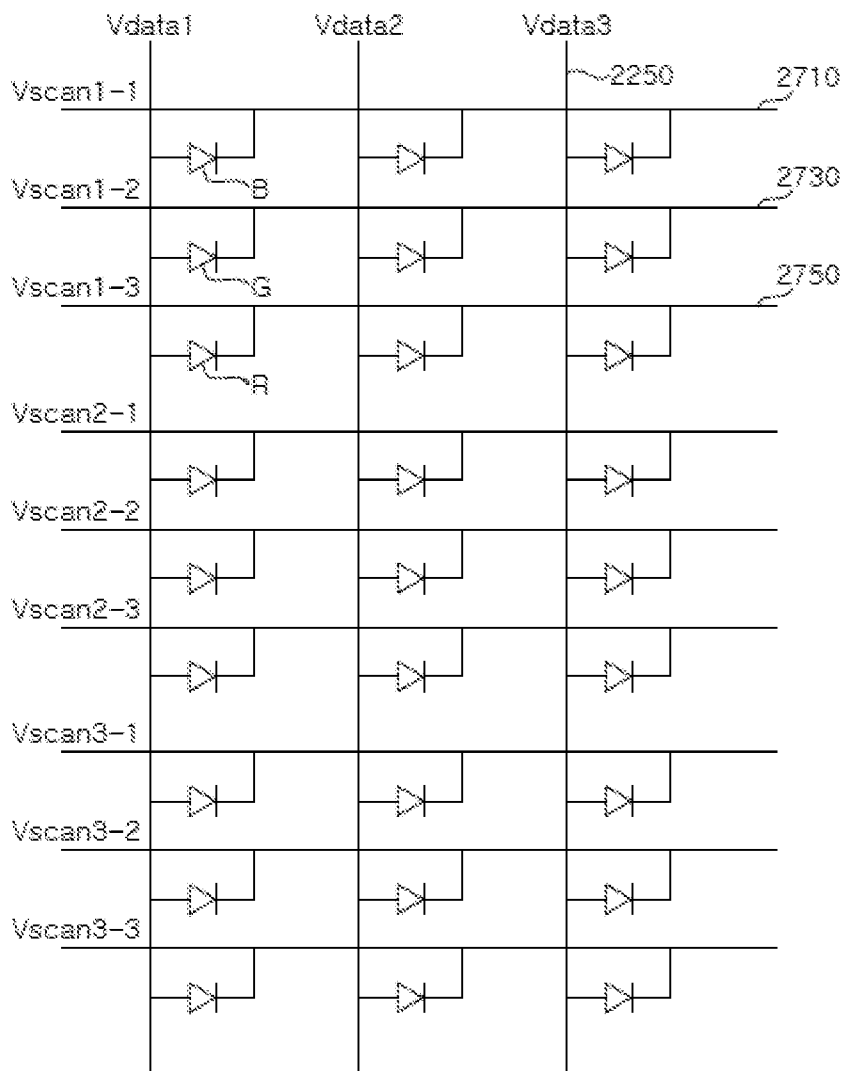


FIG. 49

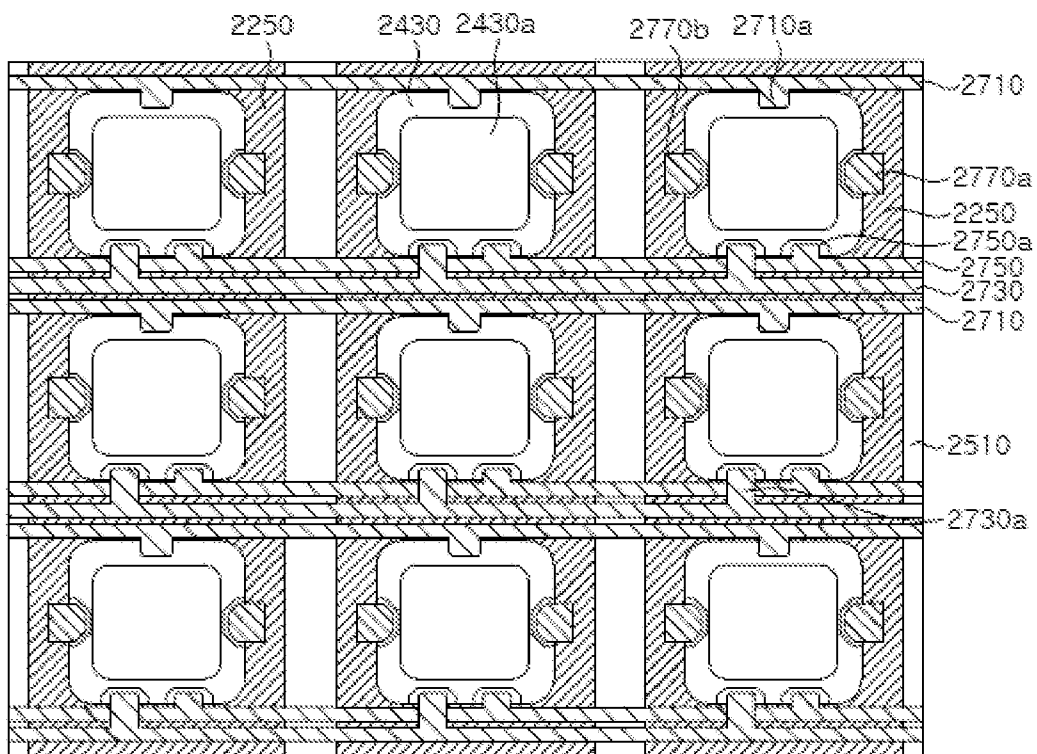


FIG. 50

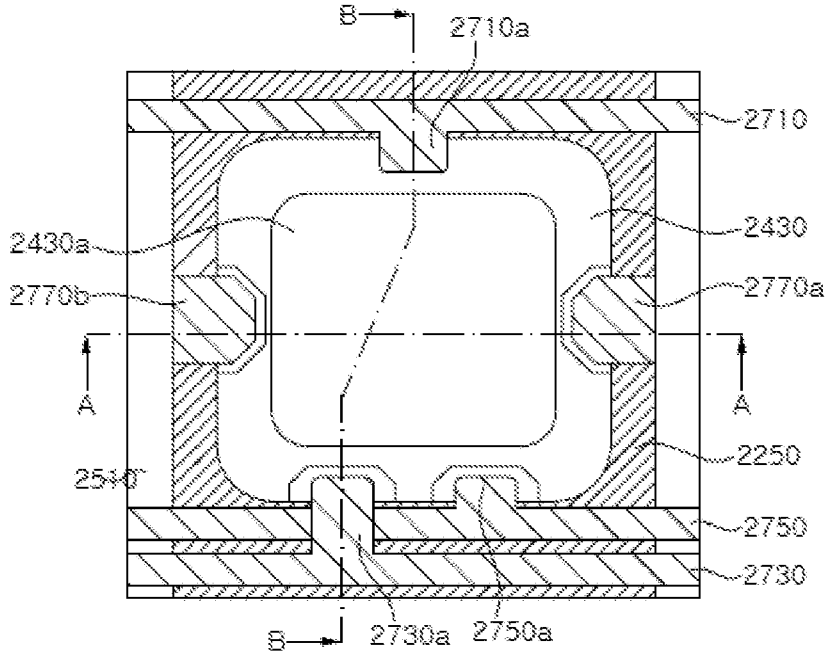


FIG. 51

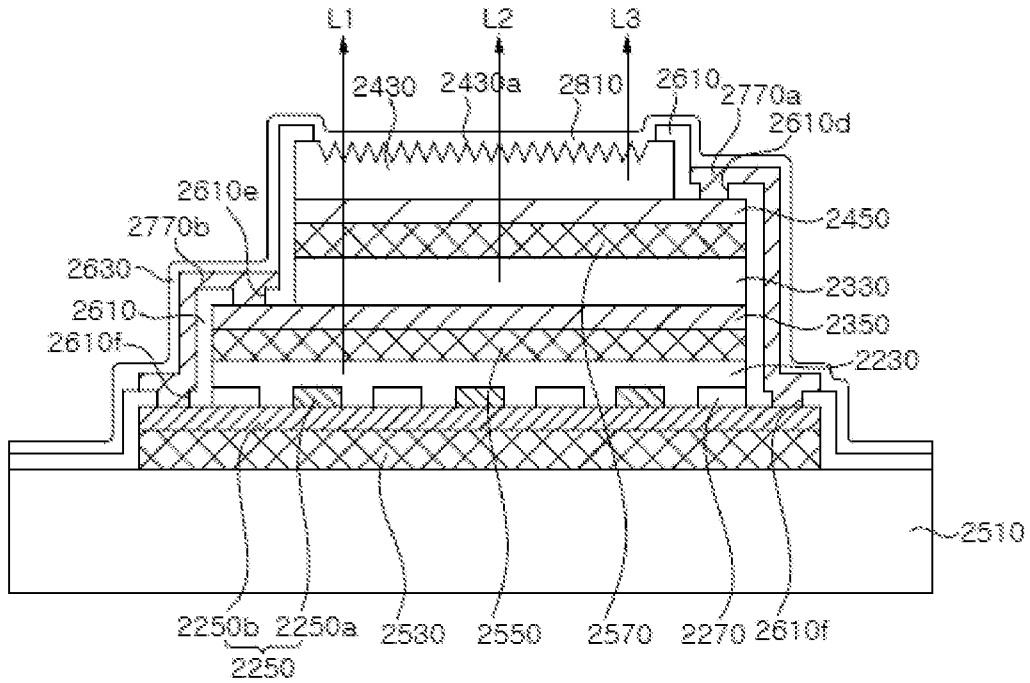


FIG. 52

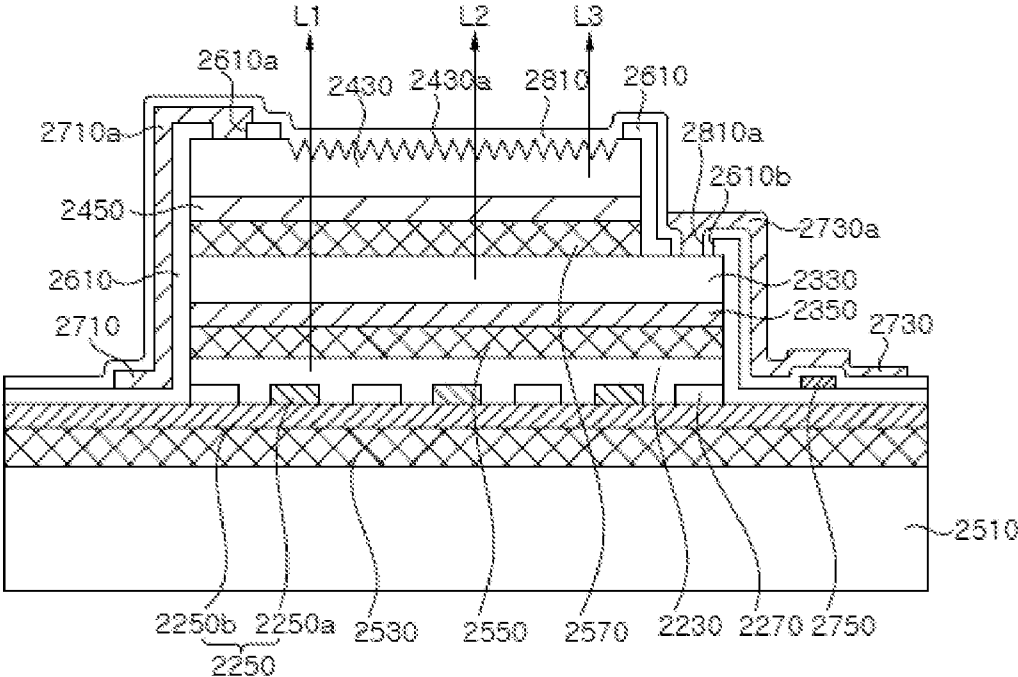


FIG. 53A

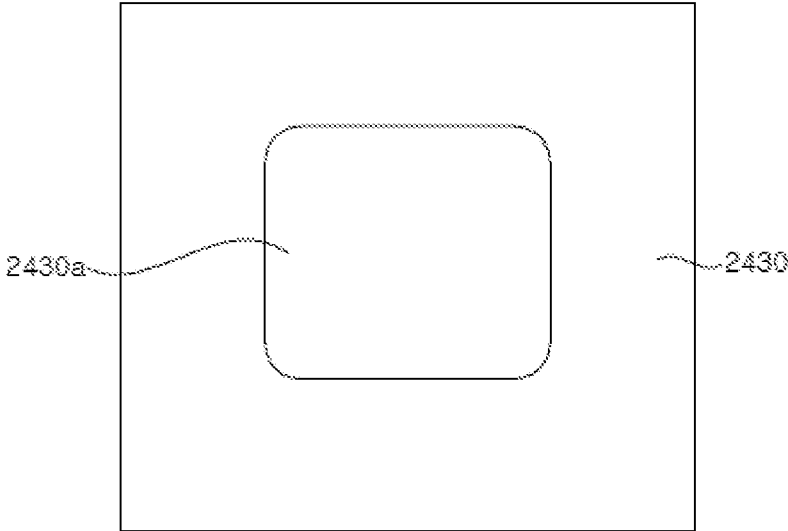


FIG. 53B

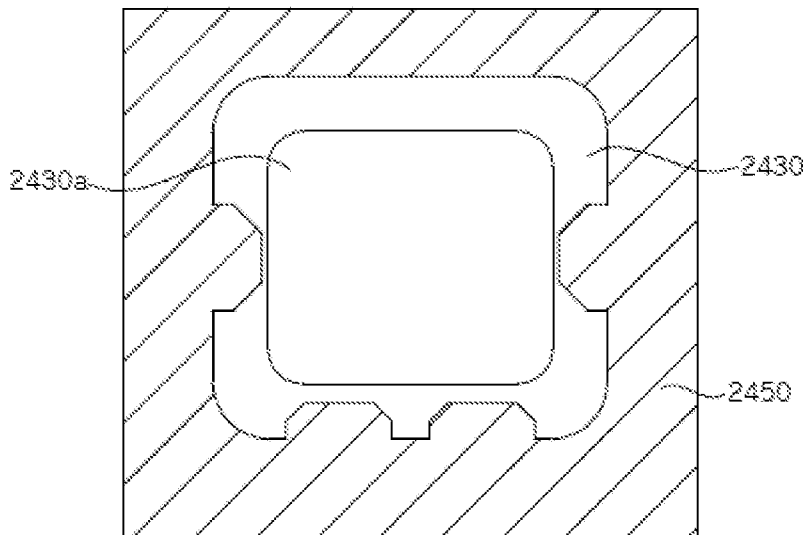


FIG. 53C

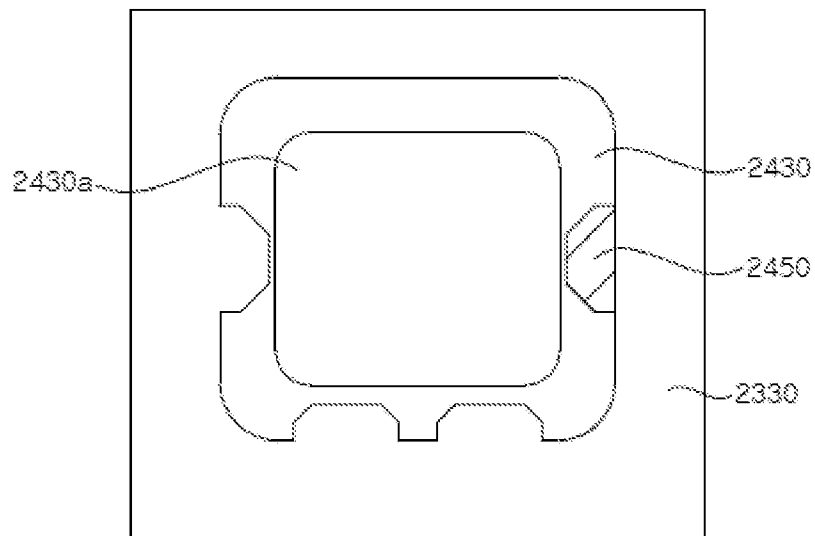


FIG. 53D

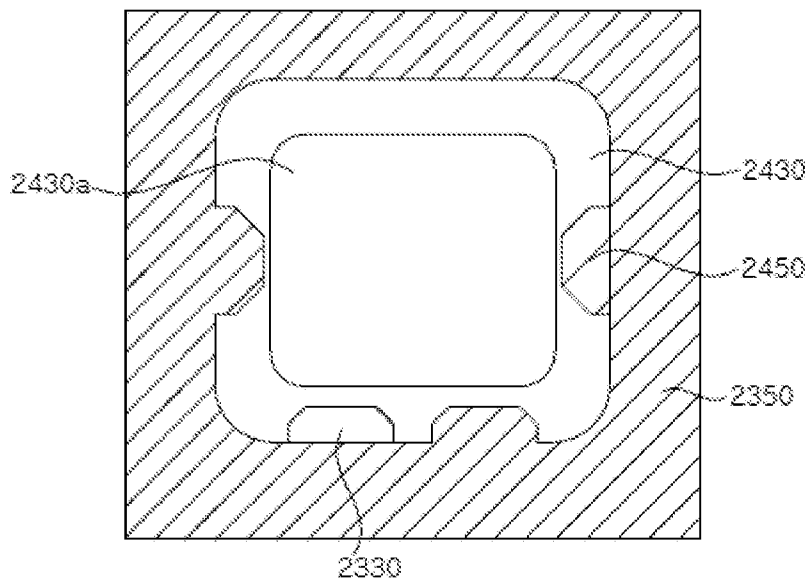


FIG. 53E

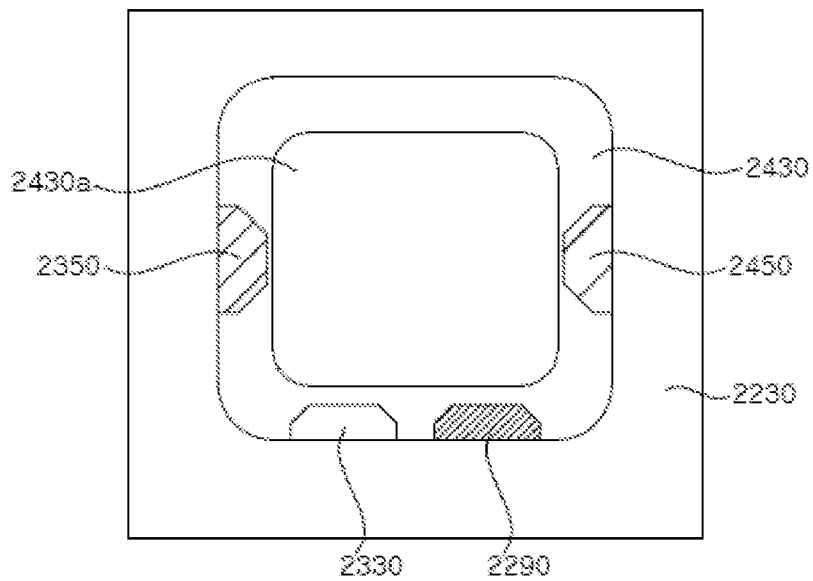


FIG. 53F

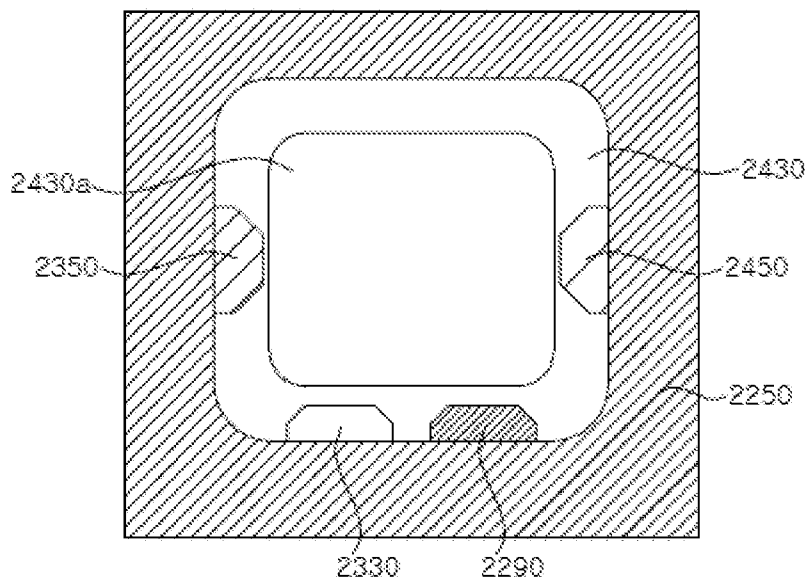


FIG. 53G

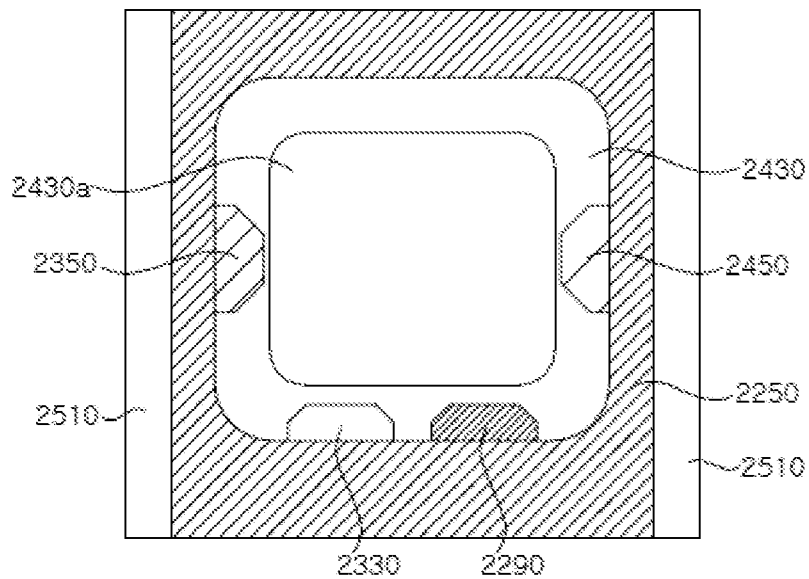


FIG. 53H

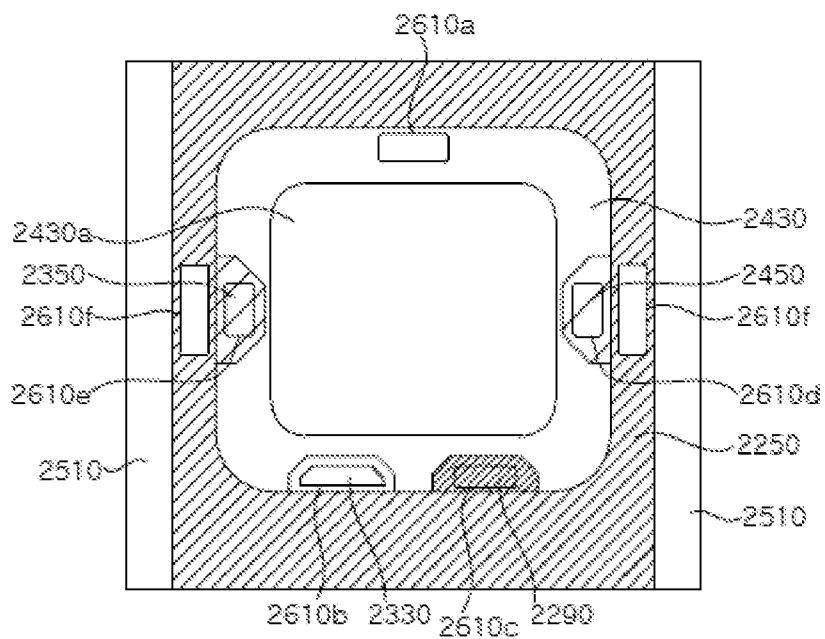


FIG. 53I

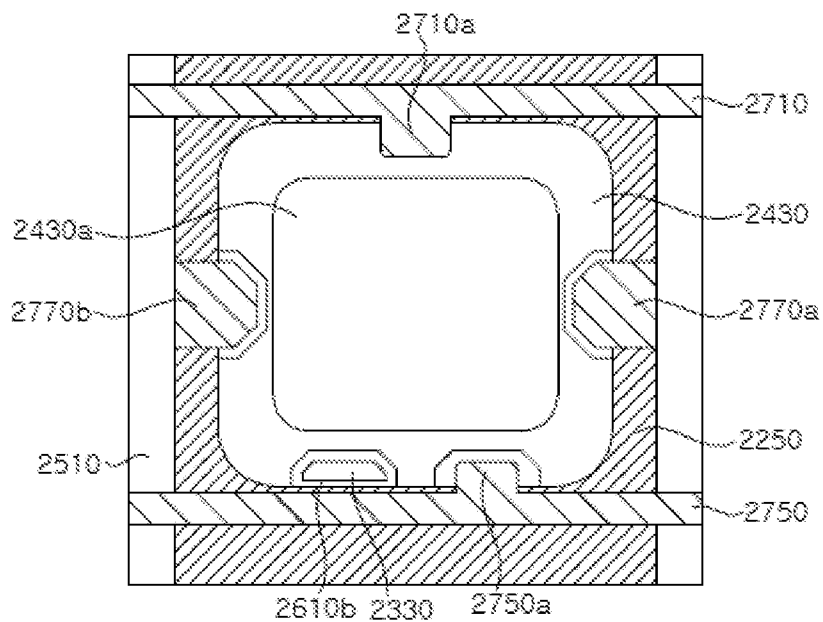


FIG. 53J

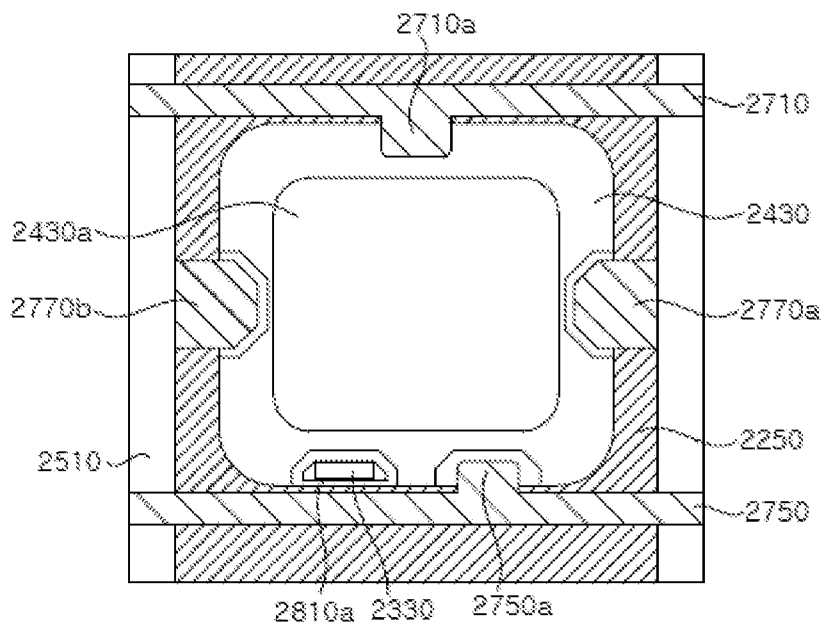


FIG. 53K

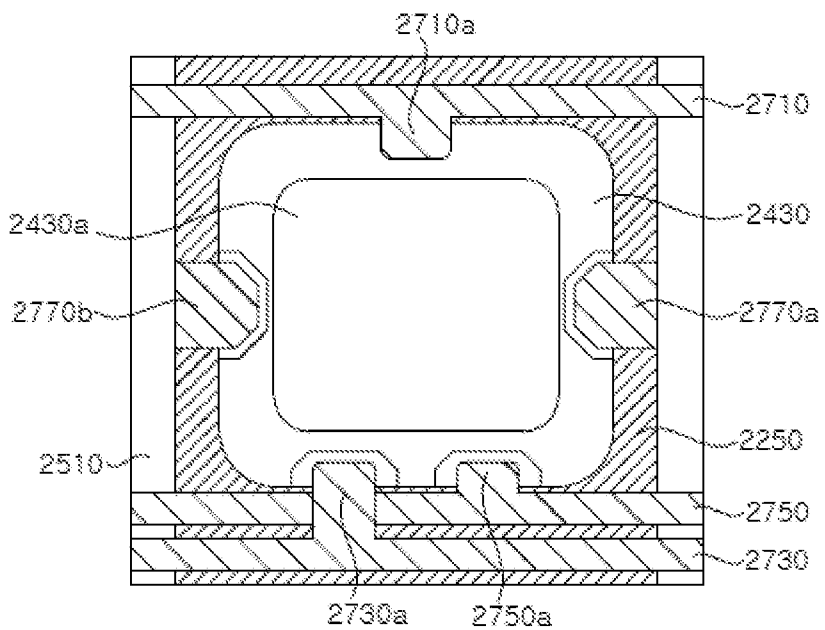


FIG. 54

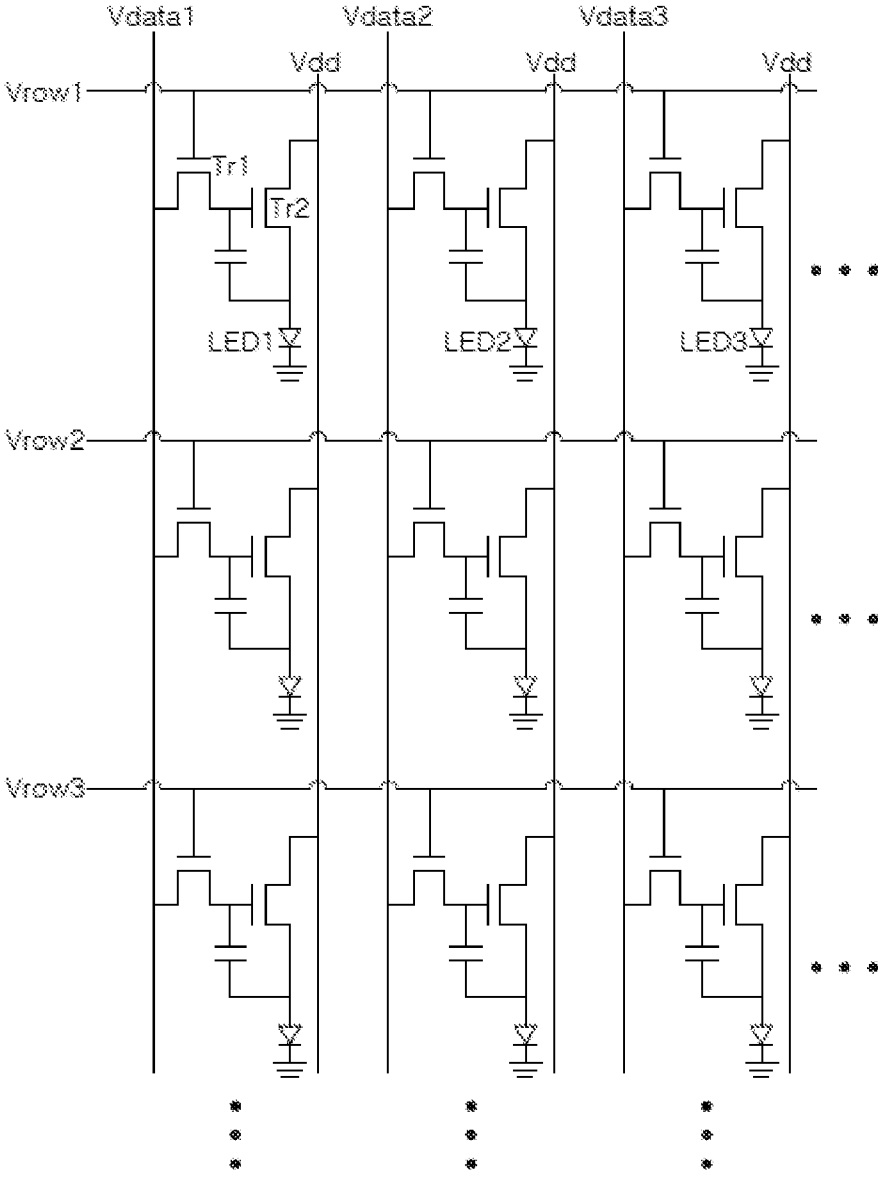


FIG. 55

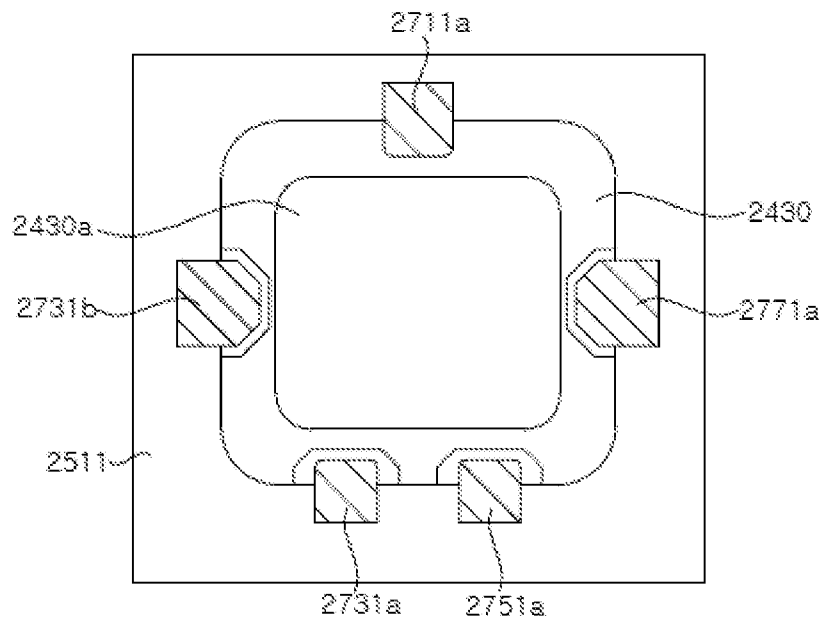


FIG. 56

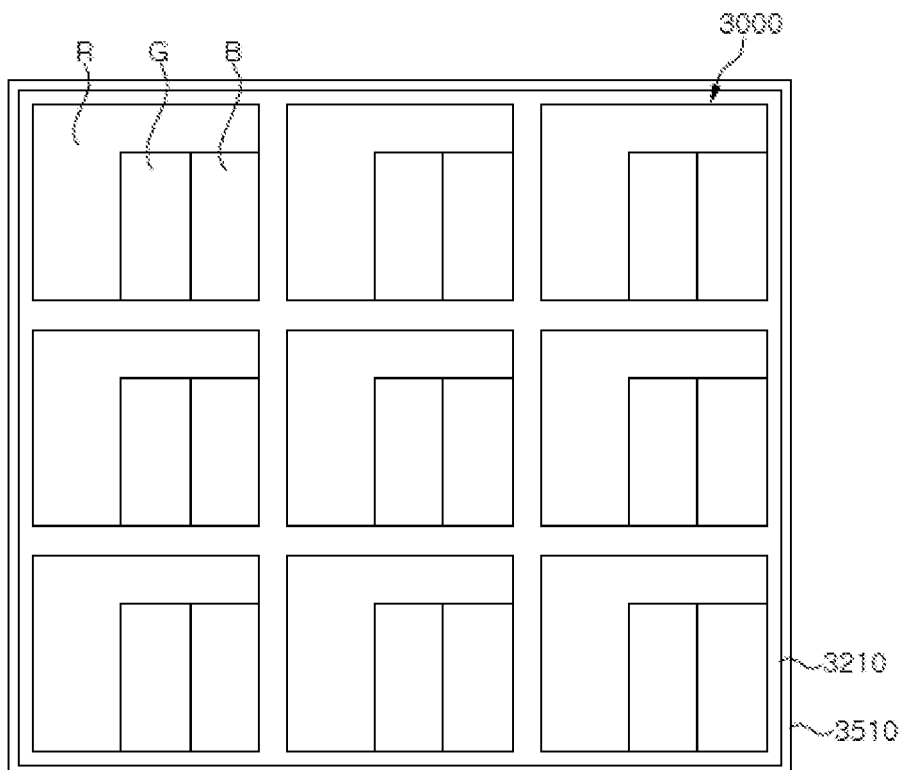


FIG. 57

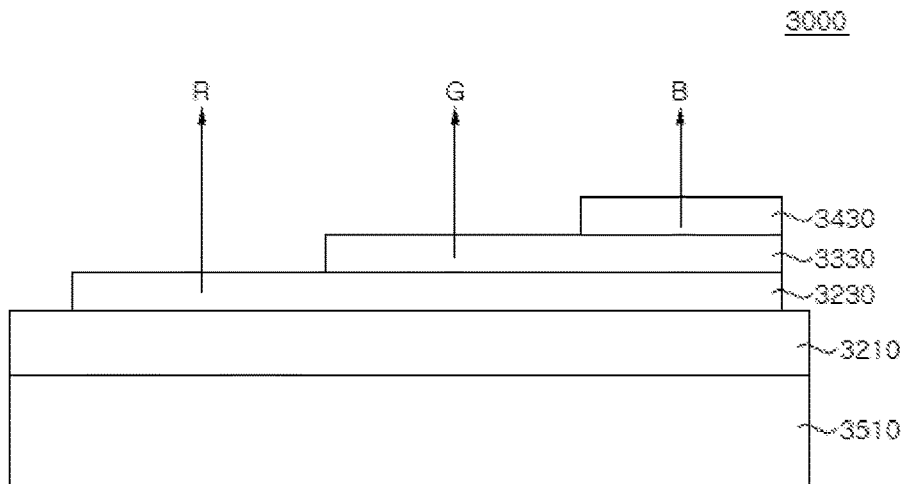


FIG. 58

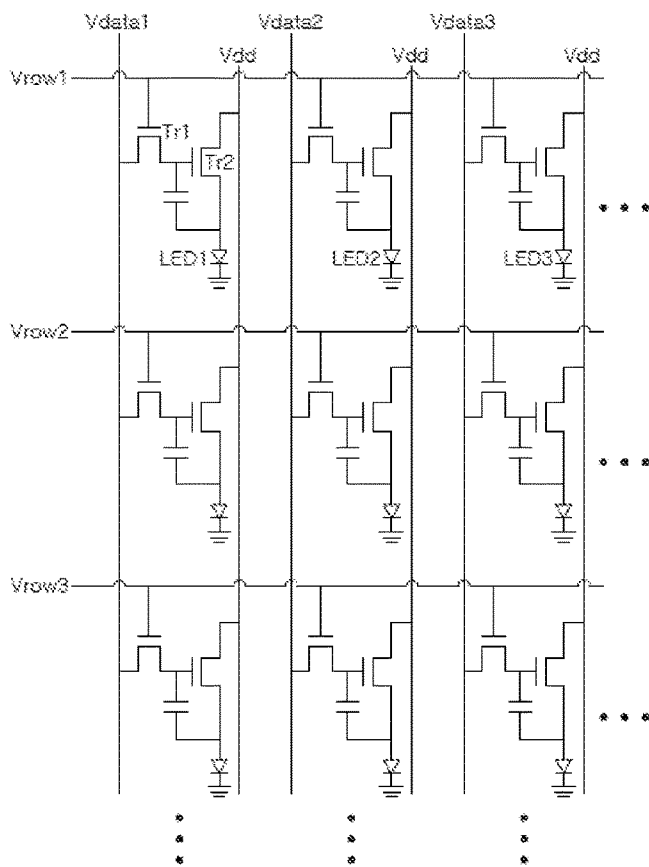


FIG. 59A

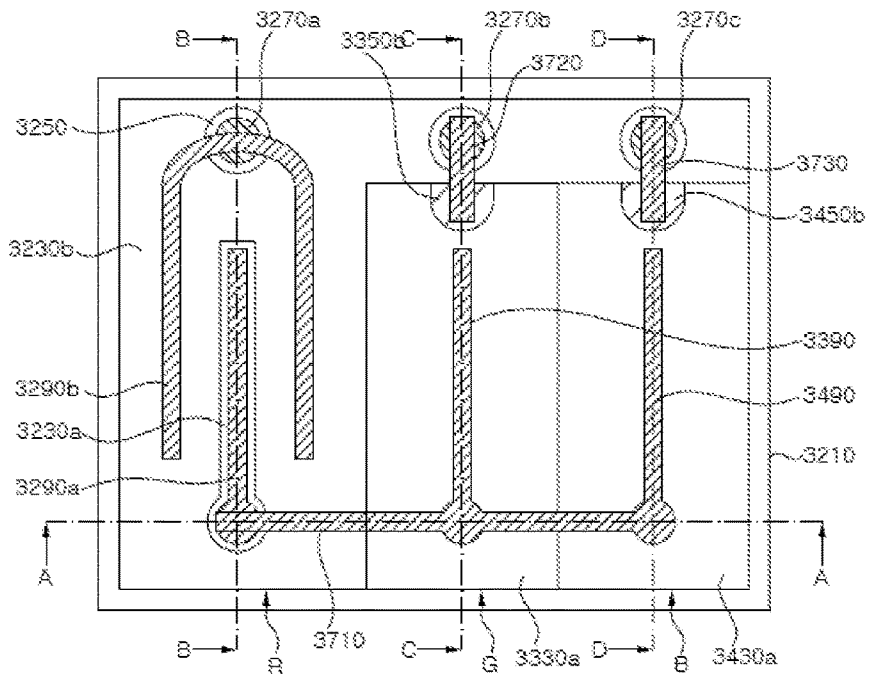


FIG. 59B

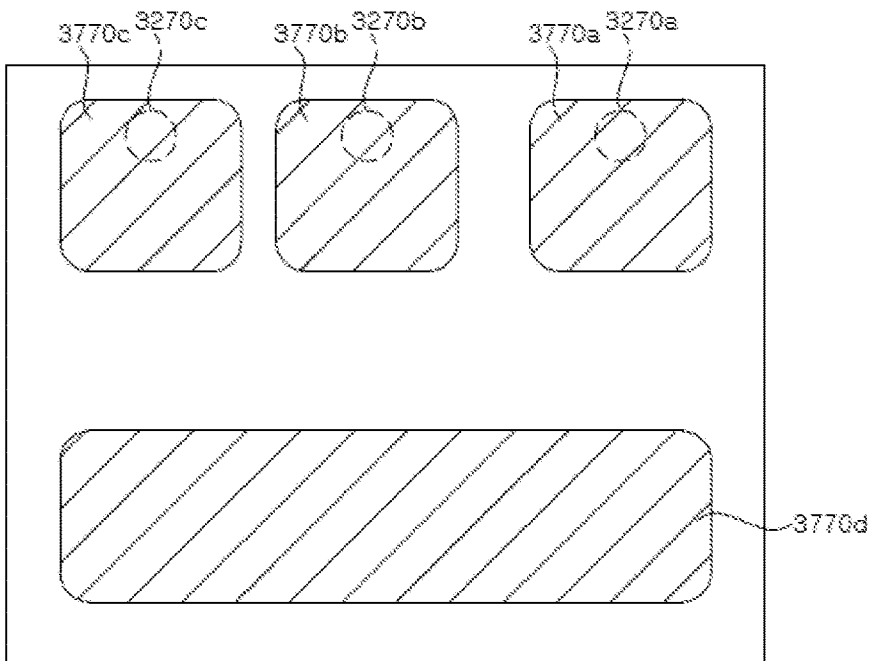


FIG. 60A

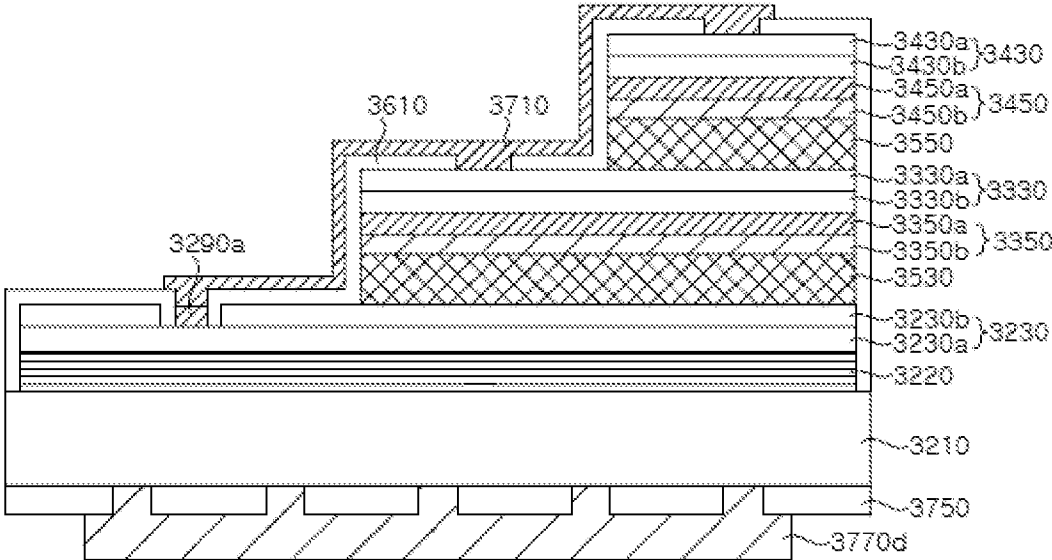


FIG. 60B

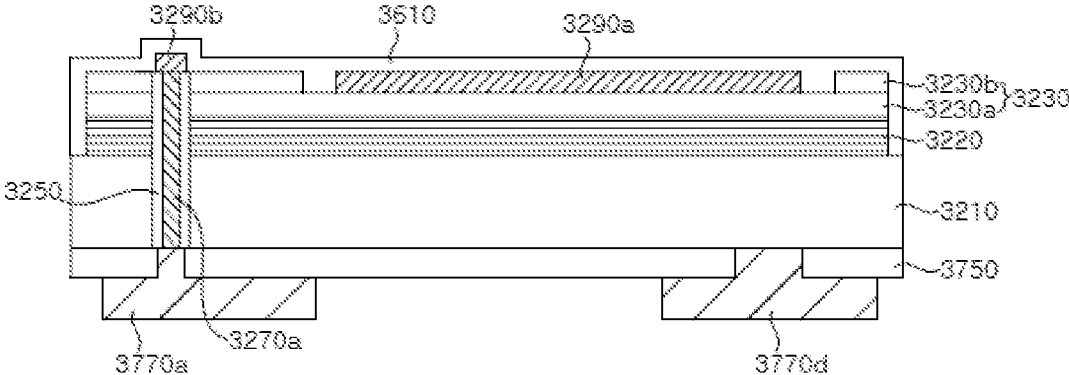


FIG. 60C

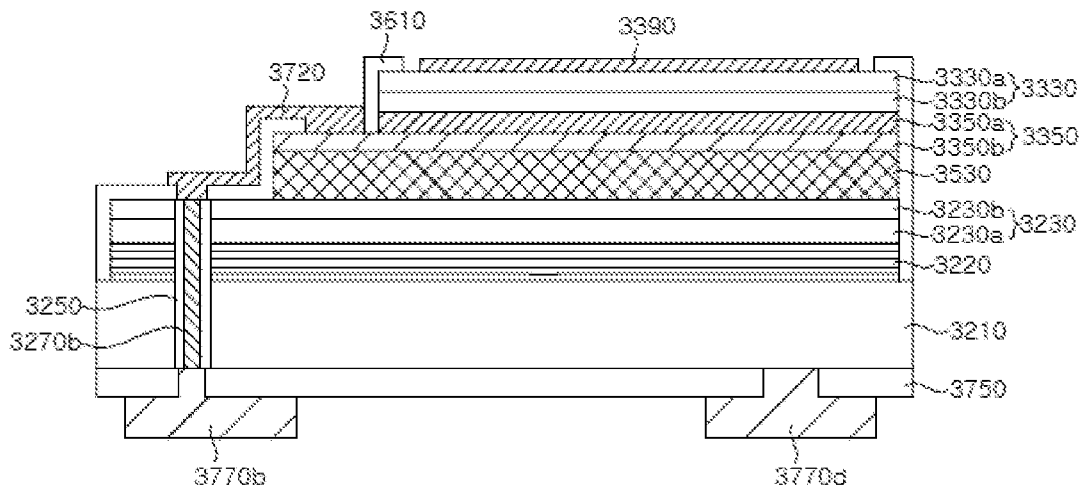


FIG. 60D

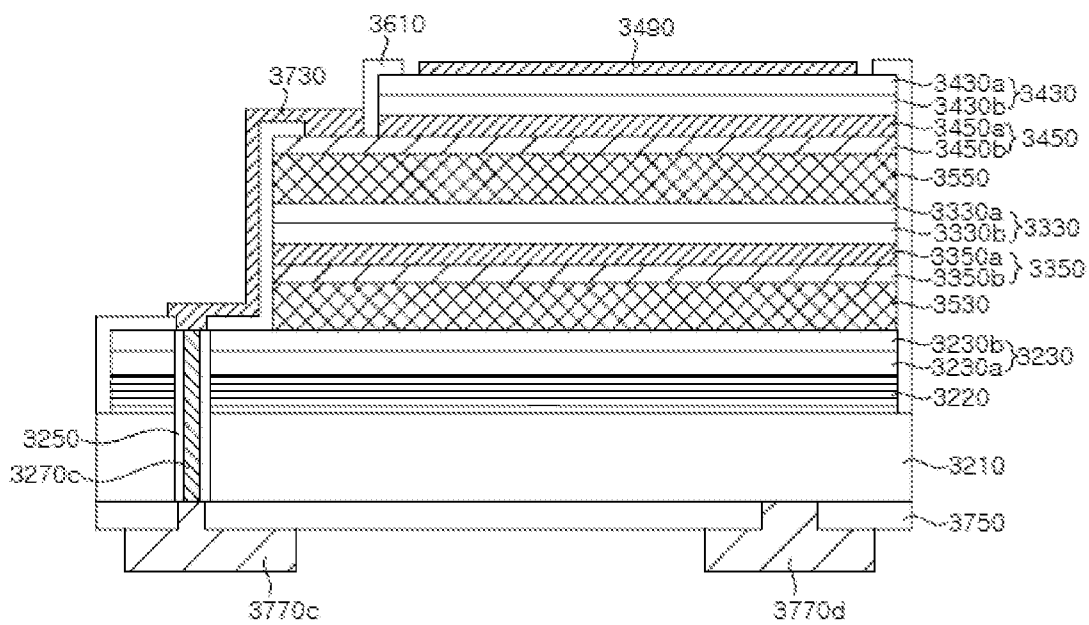


FIG. 61A

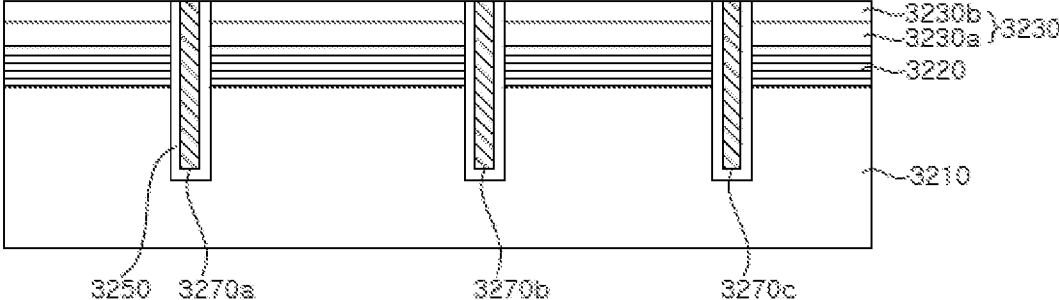


FIG. 61B

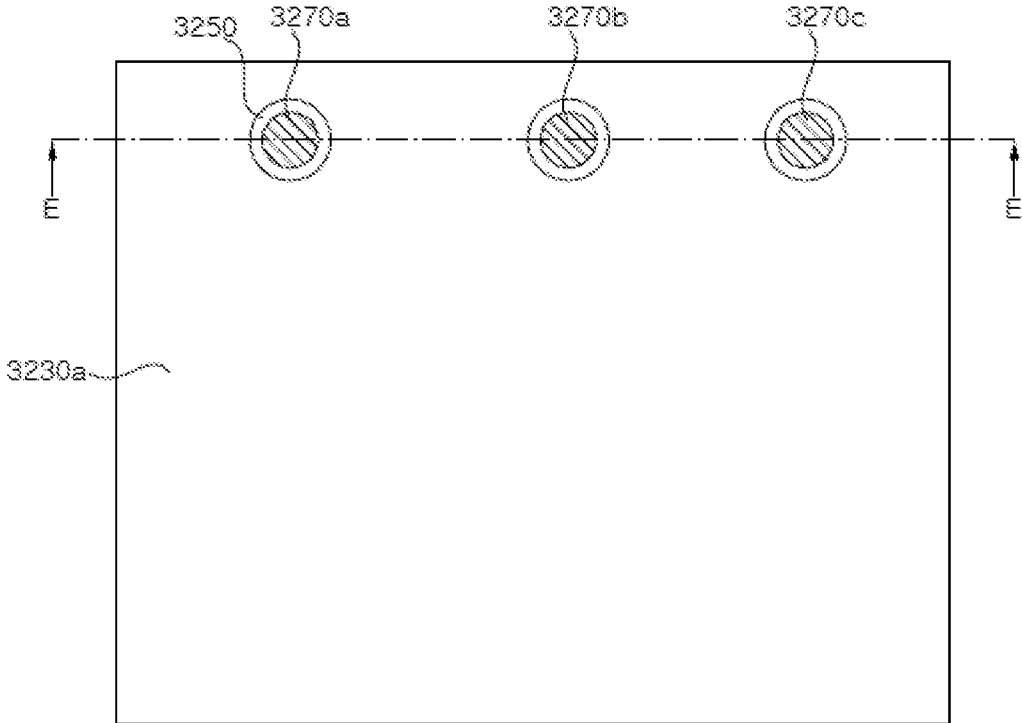


FIG. 62A

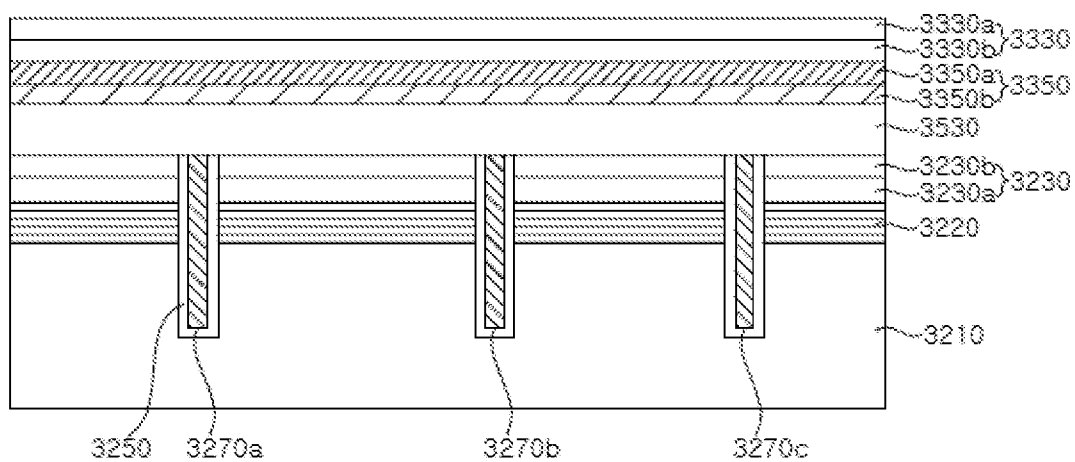


FIG. 62B

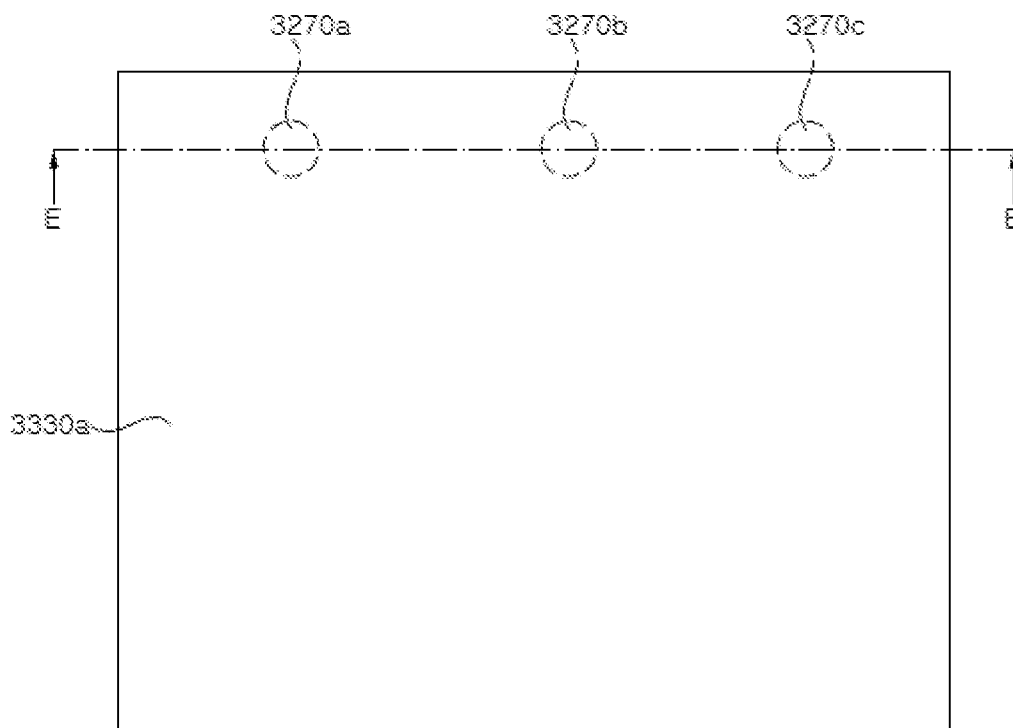


FIG. 63A

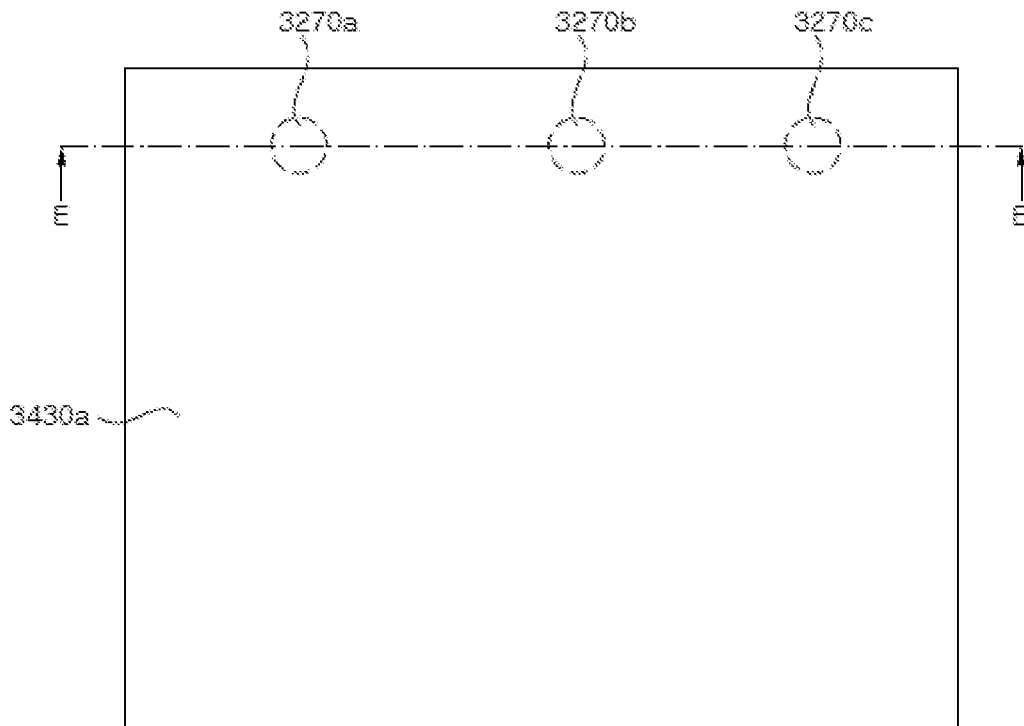


FIG. 63B

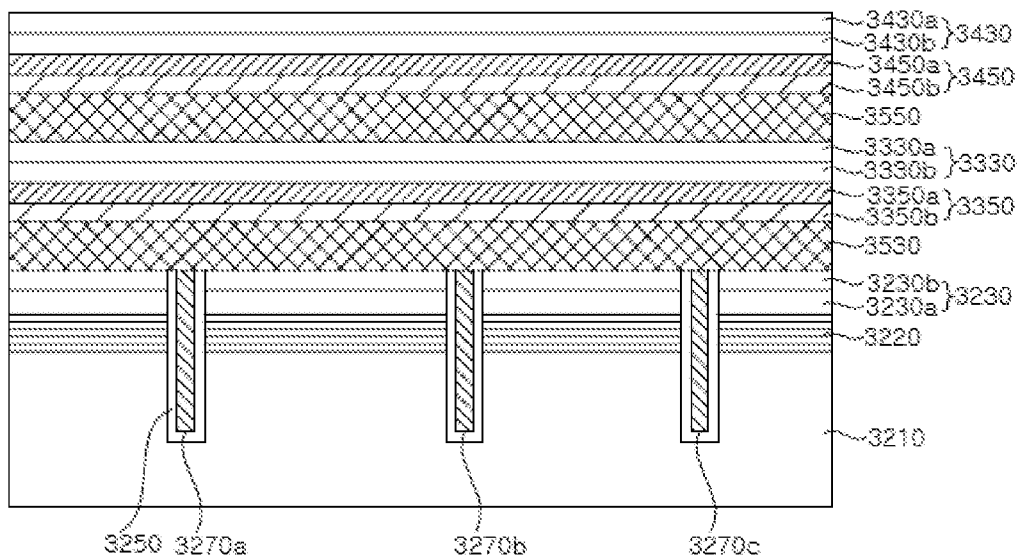


FIG. 64A

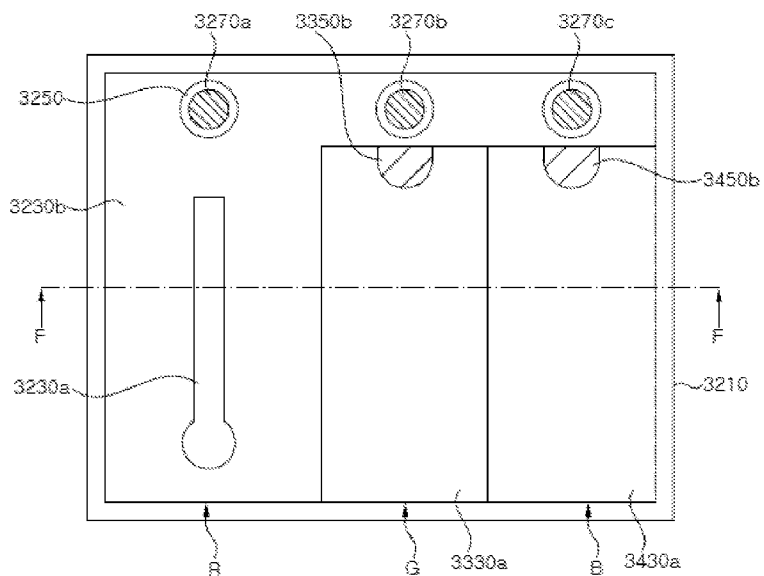


FIG. 64B

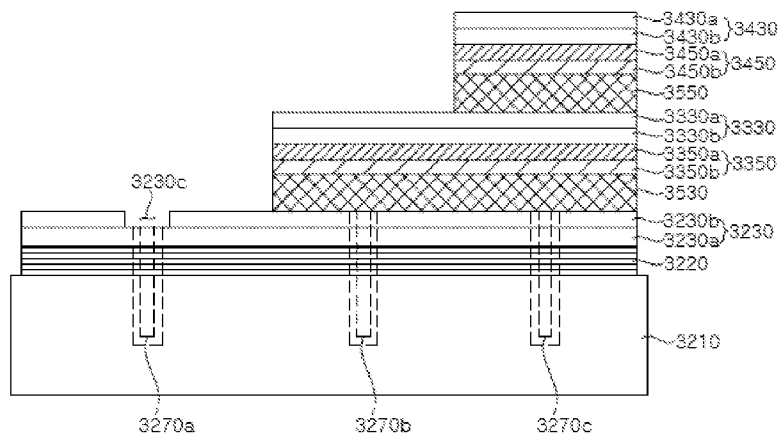


FIG. 65A

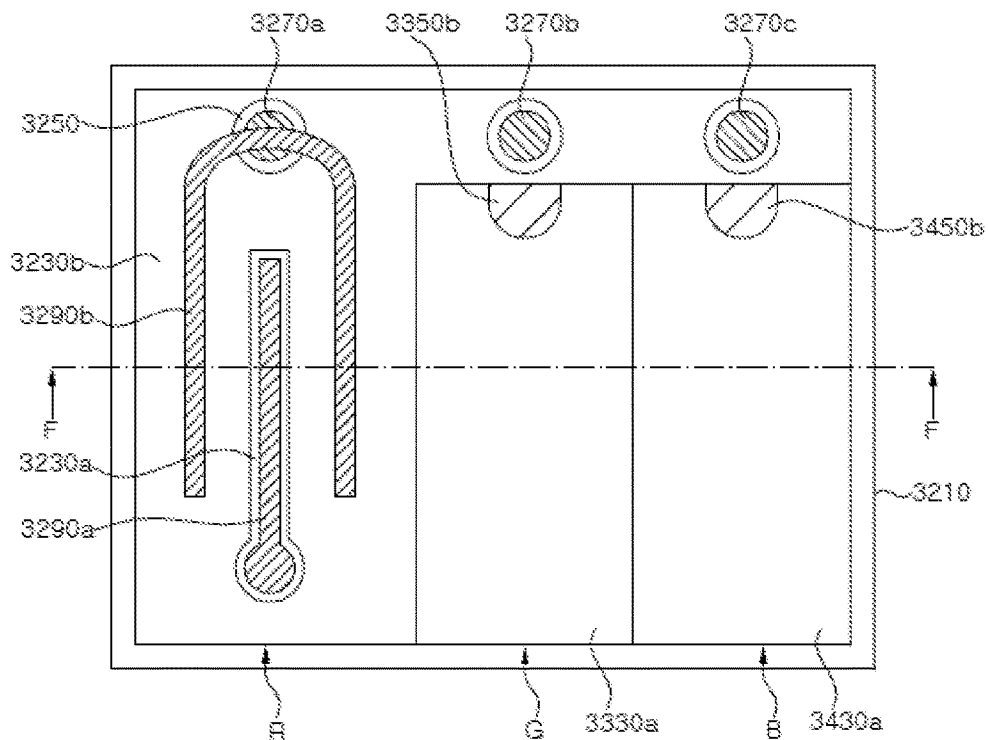


FIG. 65B

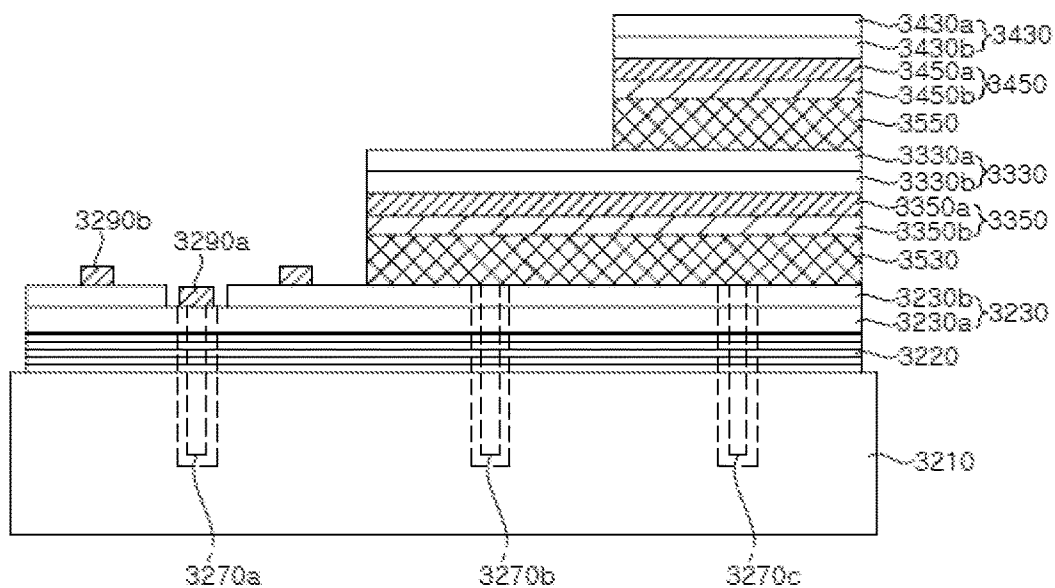


FIG. 66A

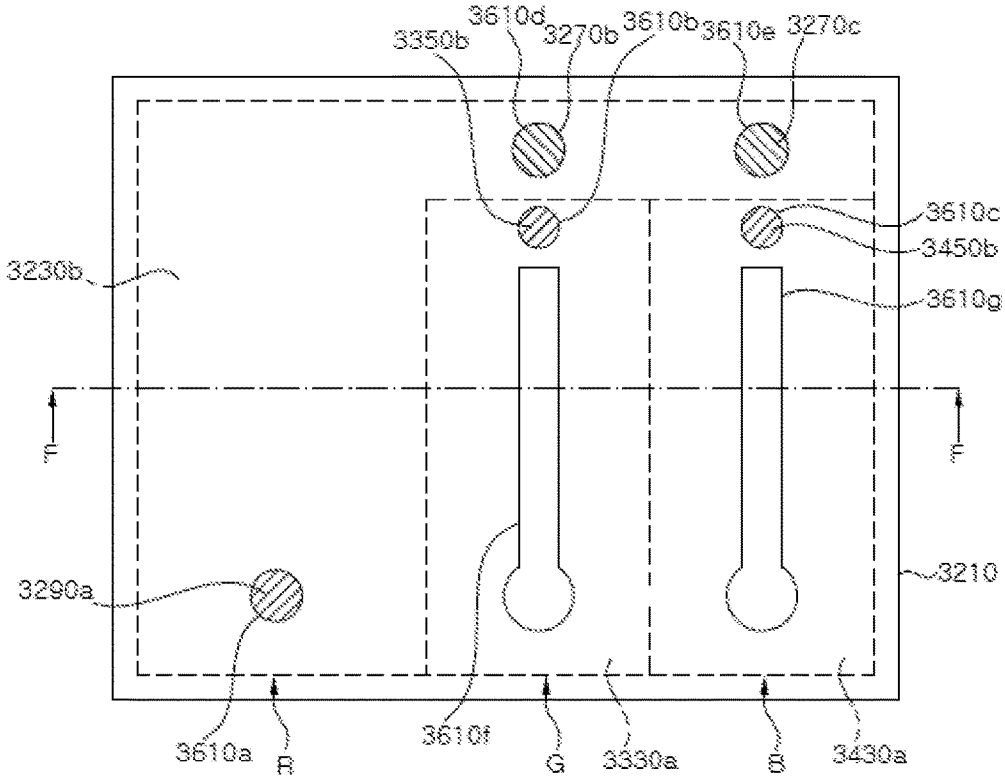


FIG. 66B

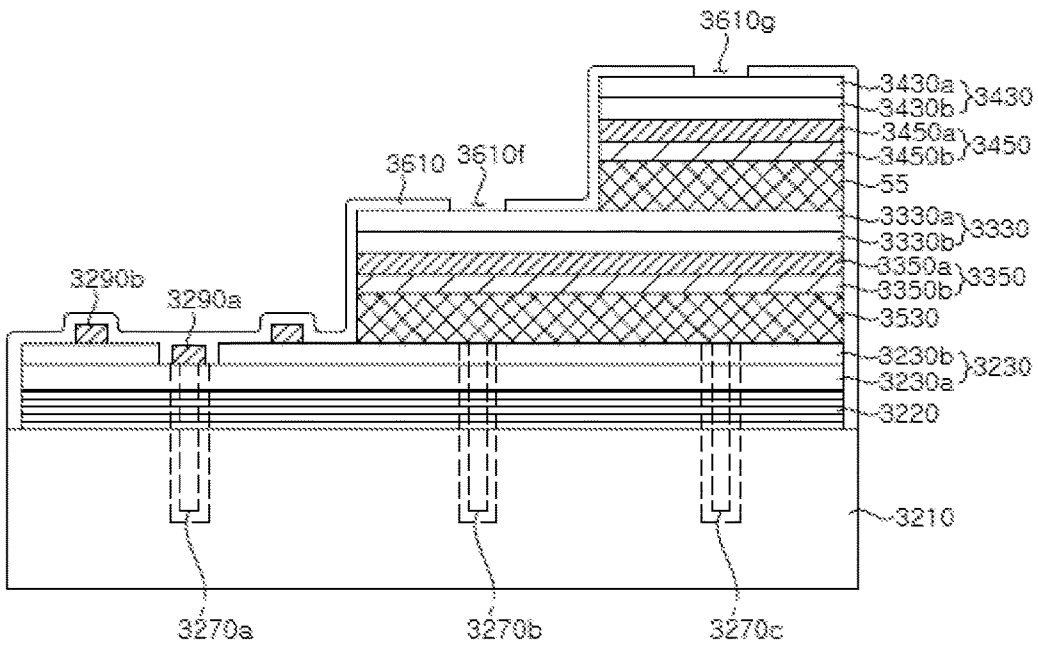


FIG. 67A

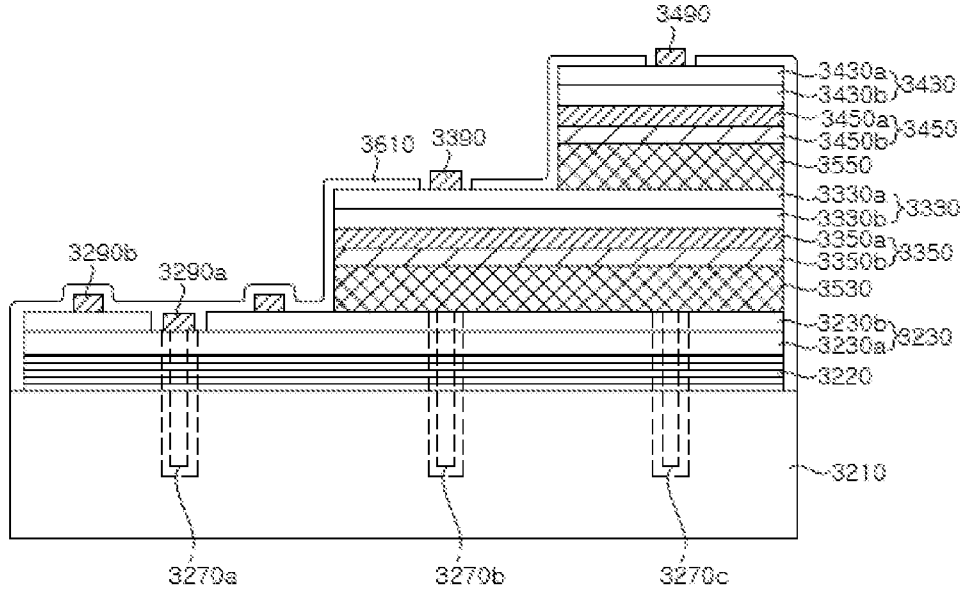


FIG. 67B

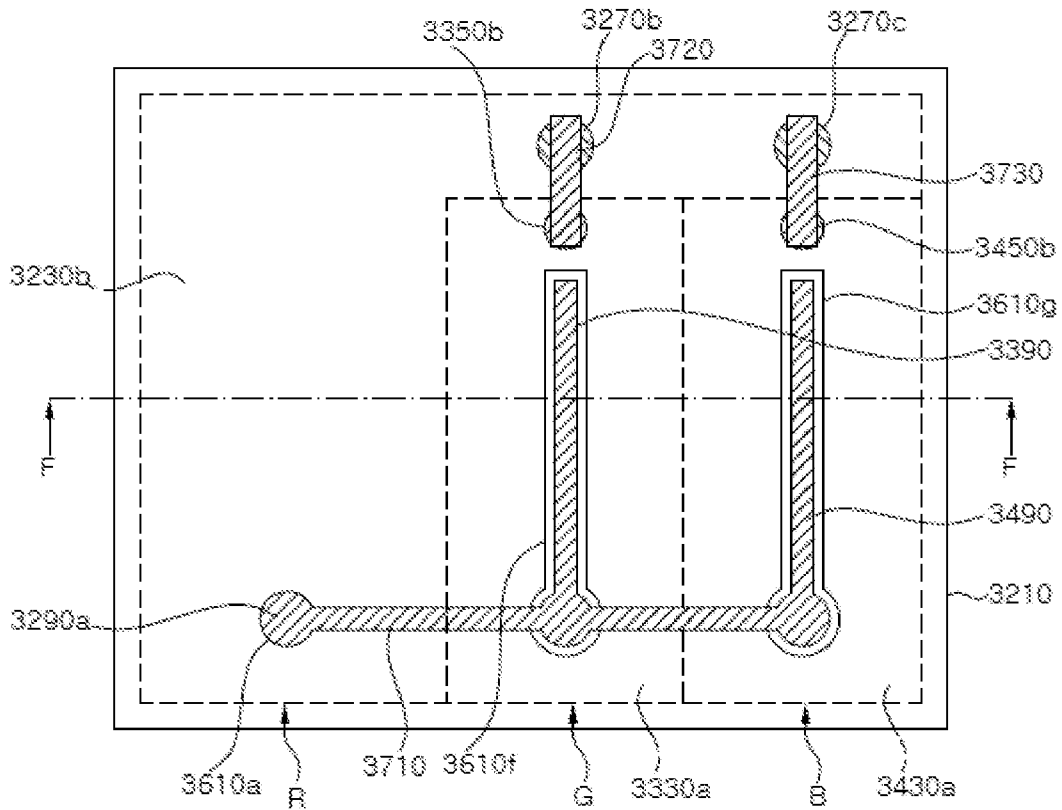


FIG. 68A

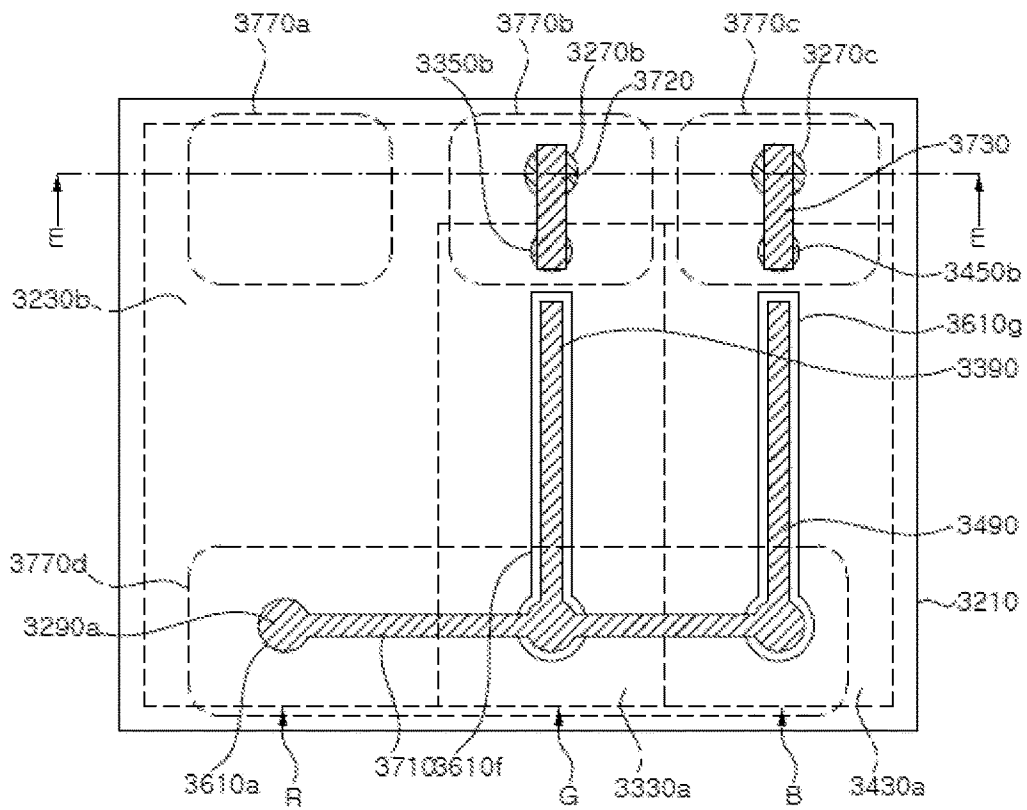


FIG. 68B

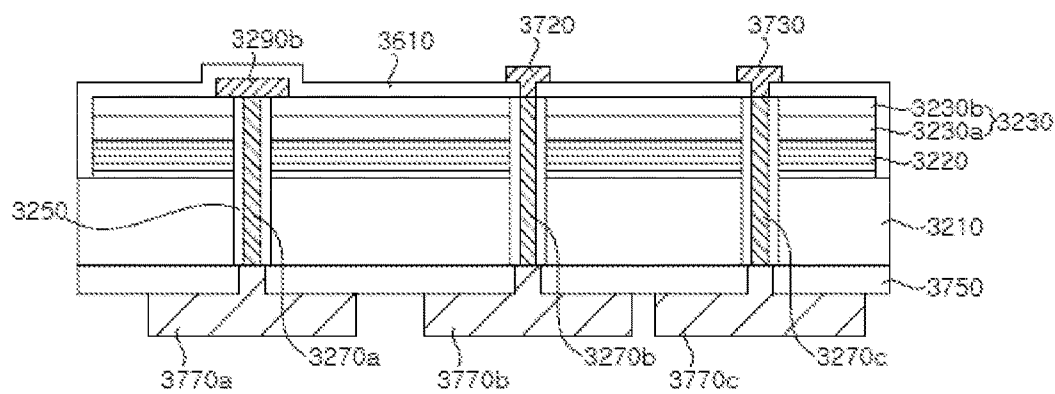


FIG. 69

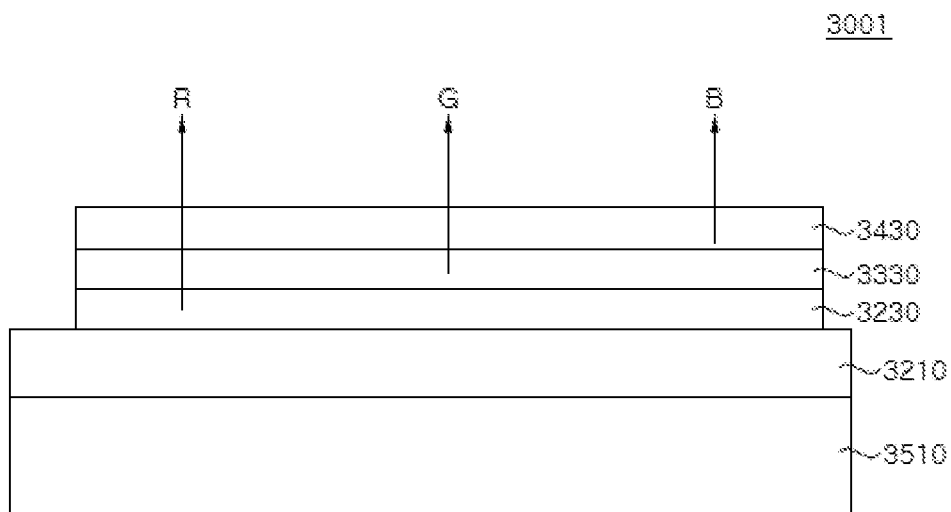


FIG. 70

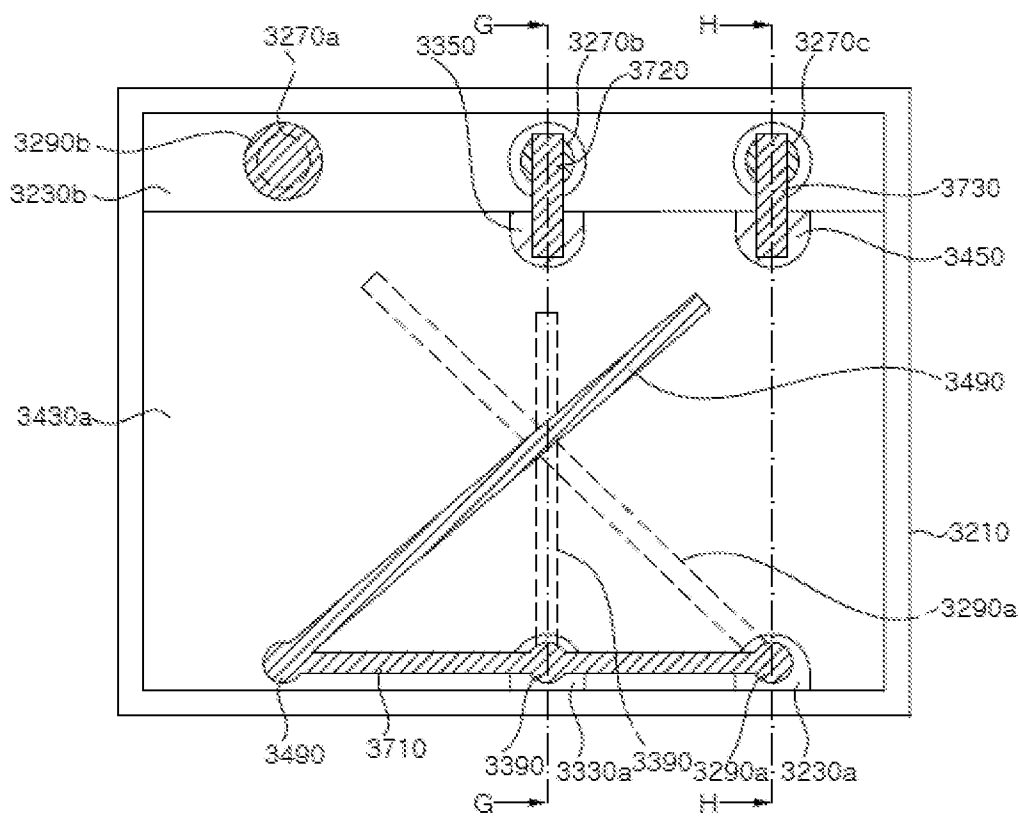


FIG. 71A

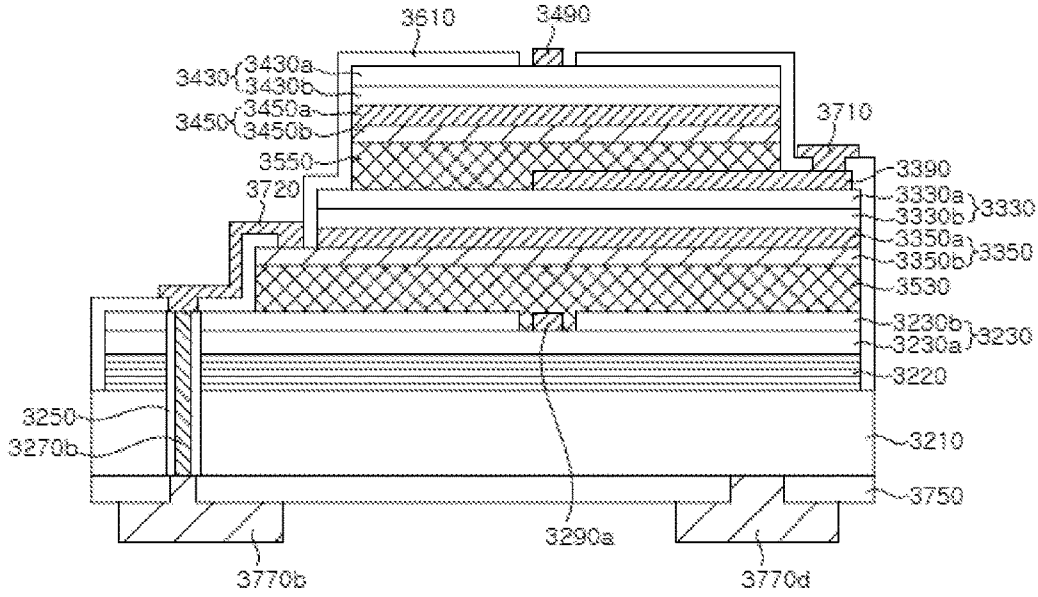


FIG. 71B

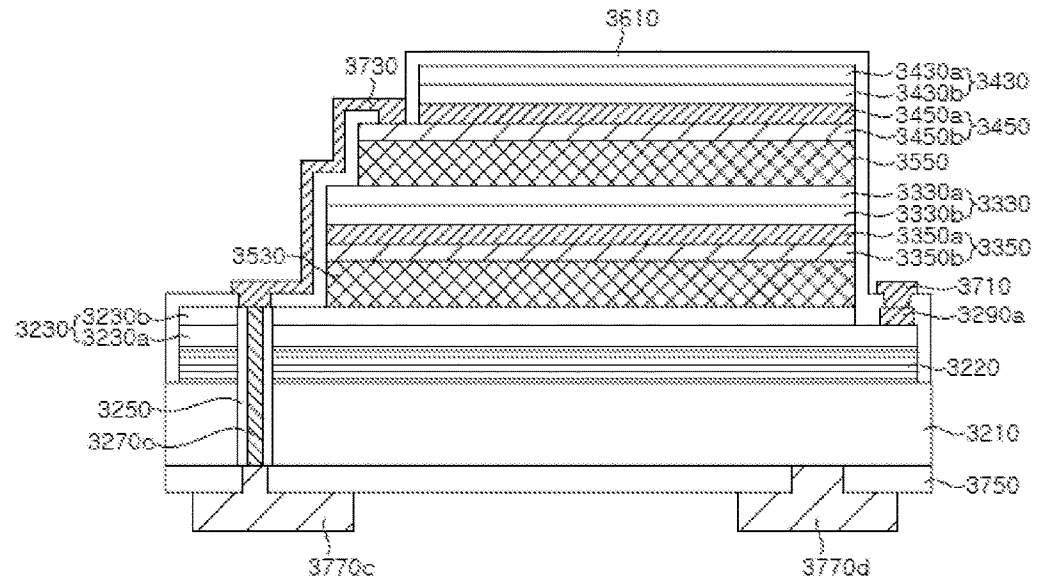


FIG. 72

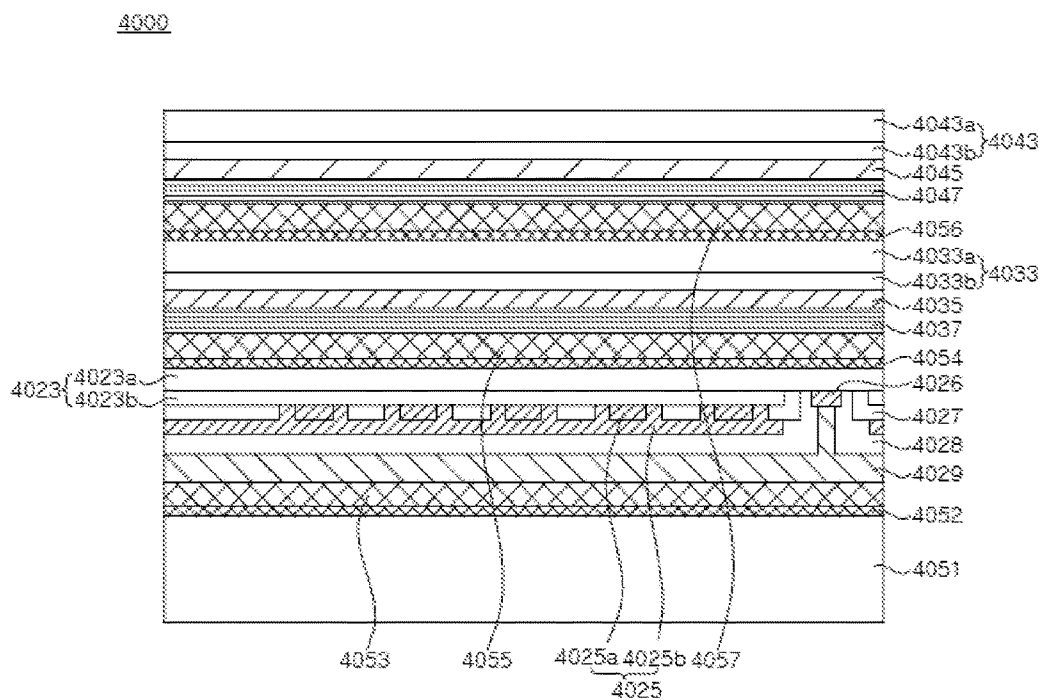


FIG. 73A

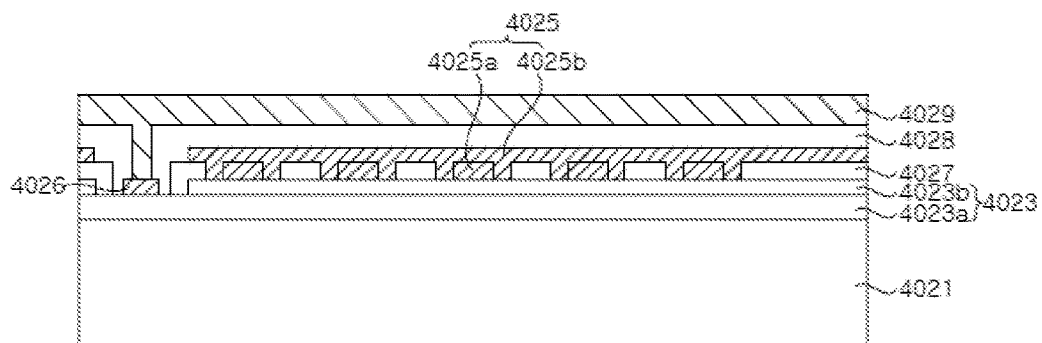


FIG. 73B

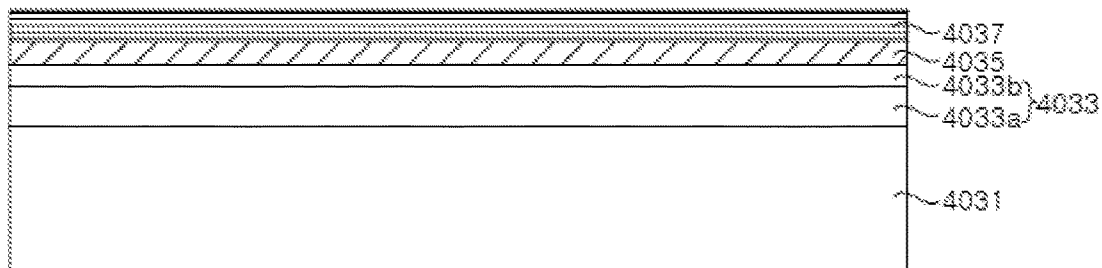


FIG. 73C

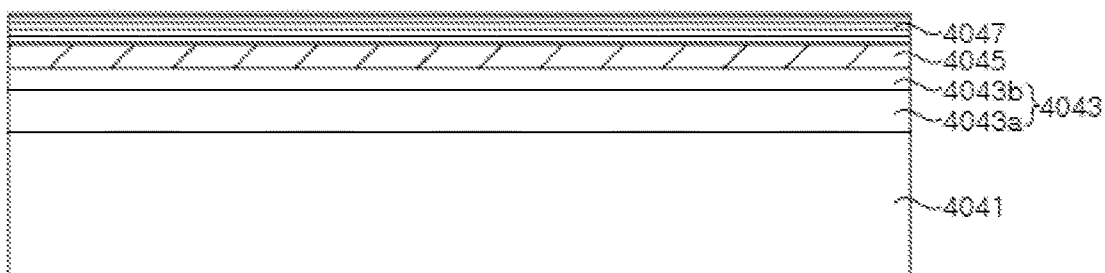


FIG. 73D

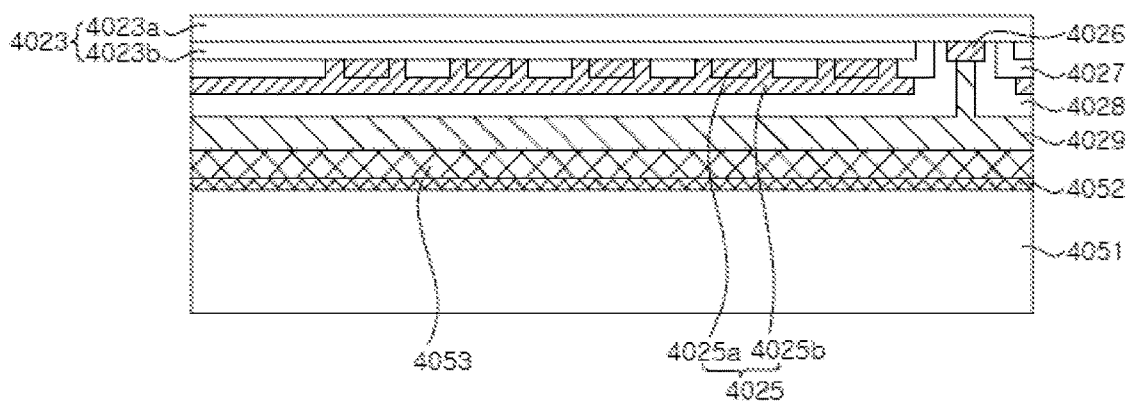


FIG. 73E

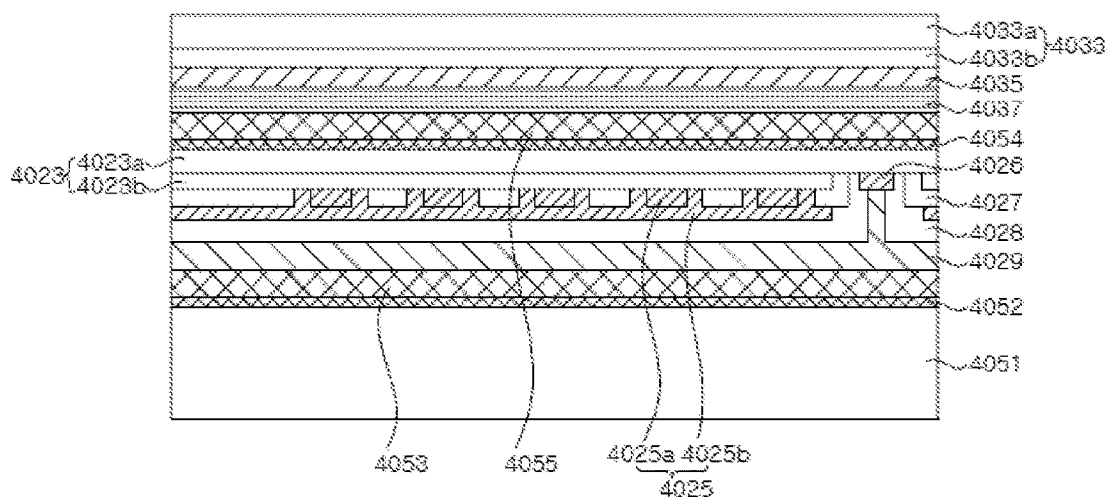


FIG. 73F

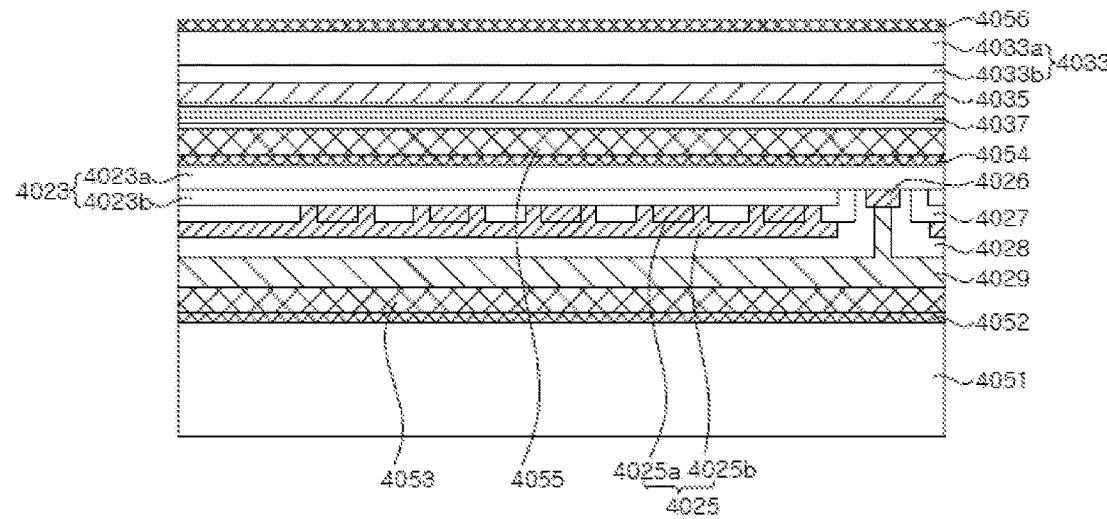


FIG. 74

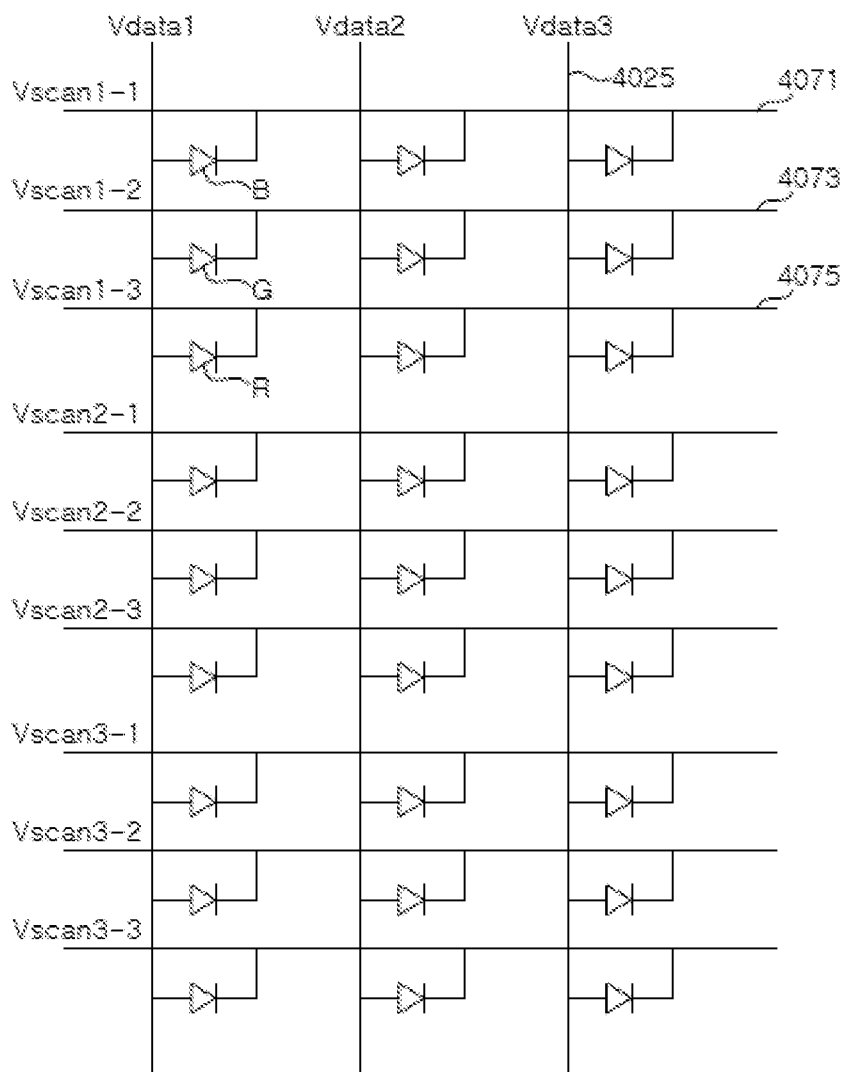


FIG. 75

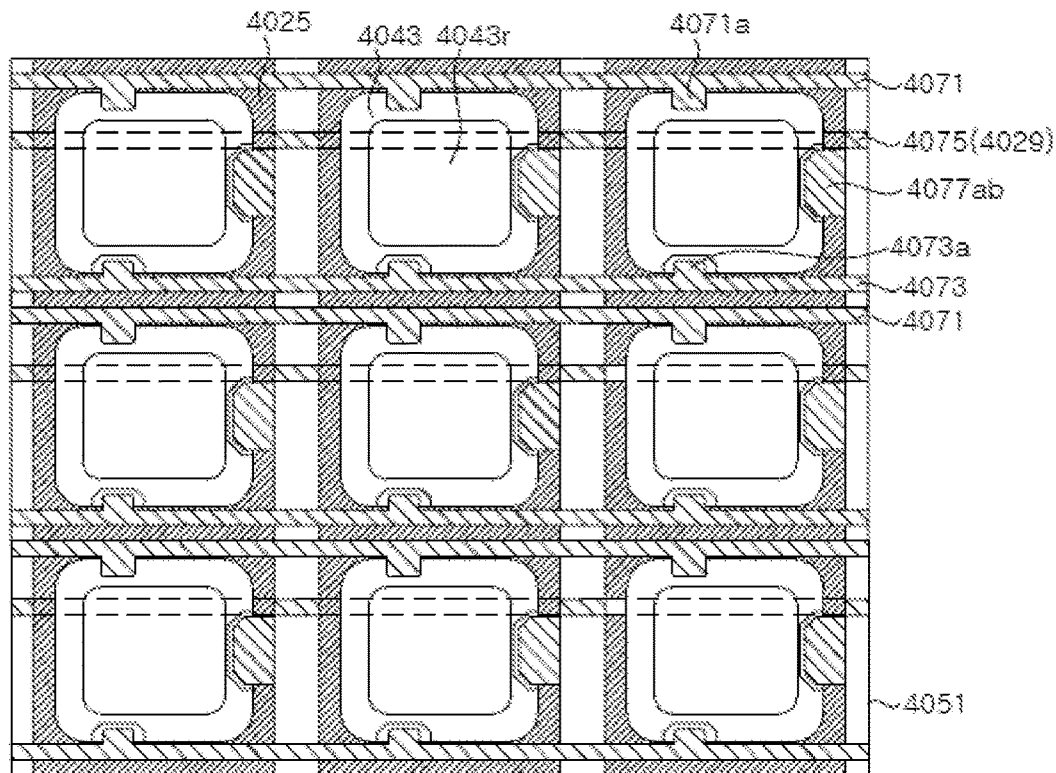


FIG. 76

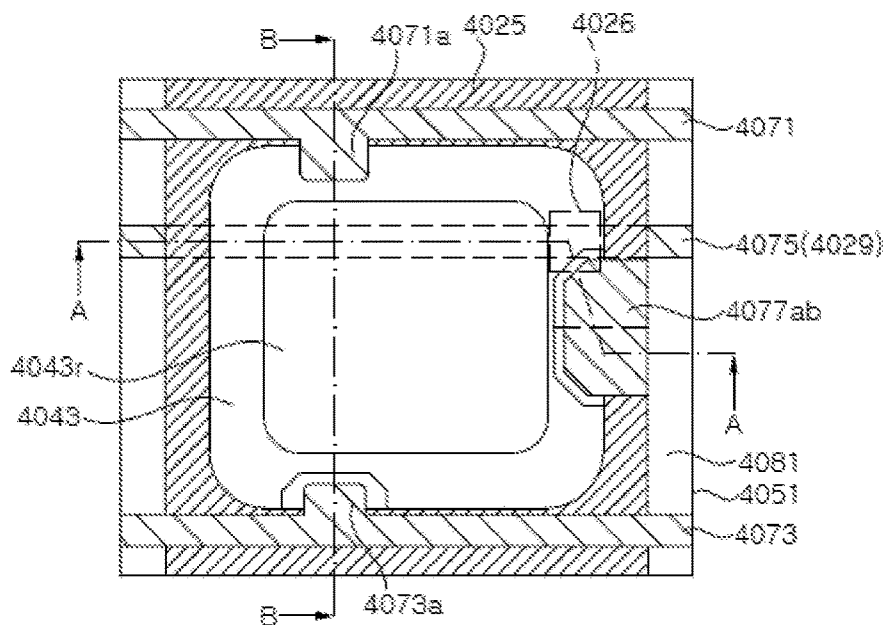


FIG. 77

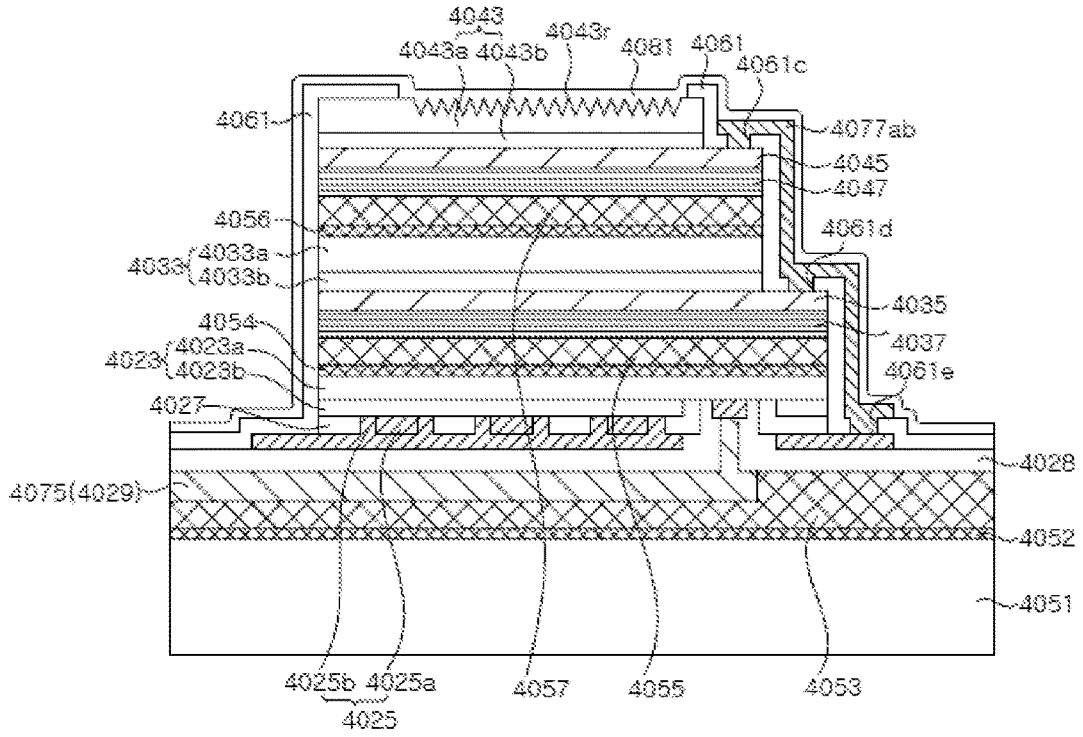


FIG. 78

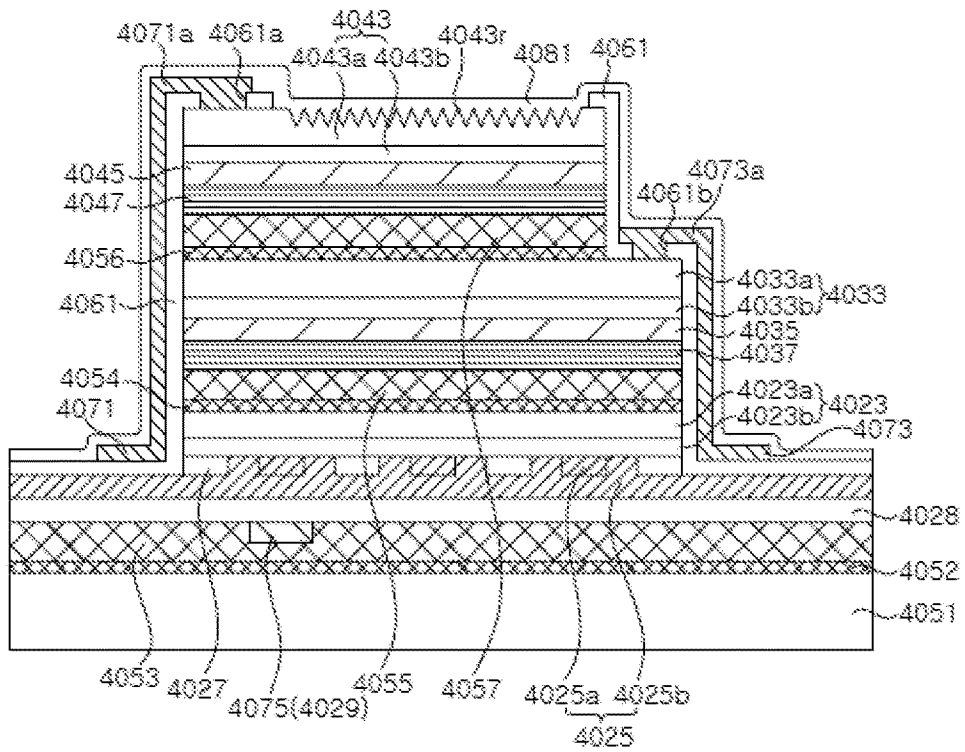


FIG. 79A

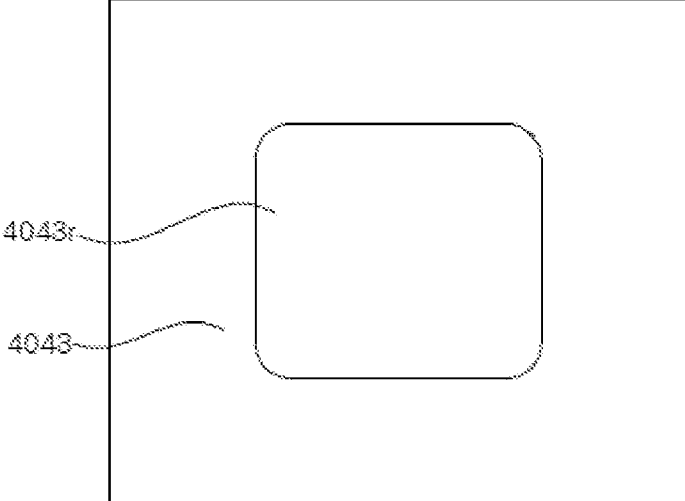


FIG. 79B

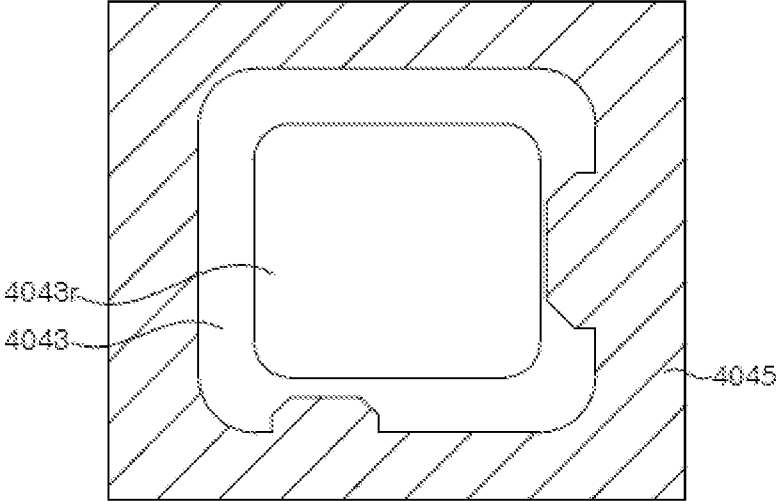


FIG. 79C

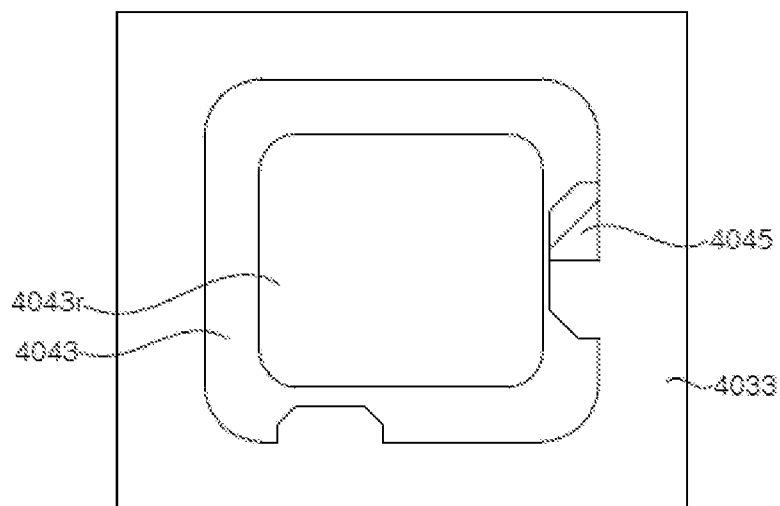


FIG. 79D

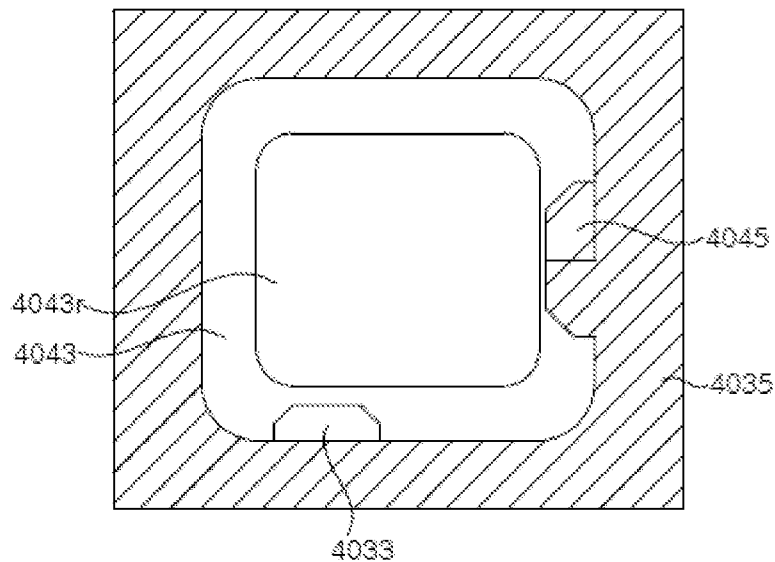


FIG. 79E

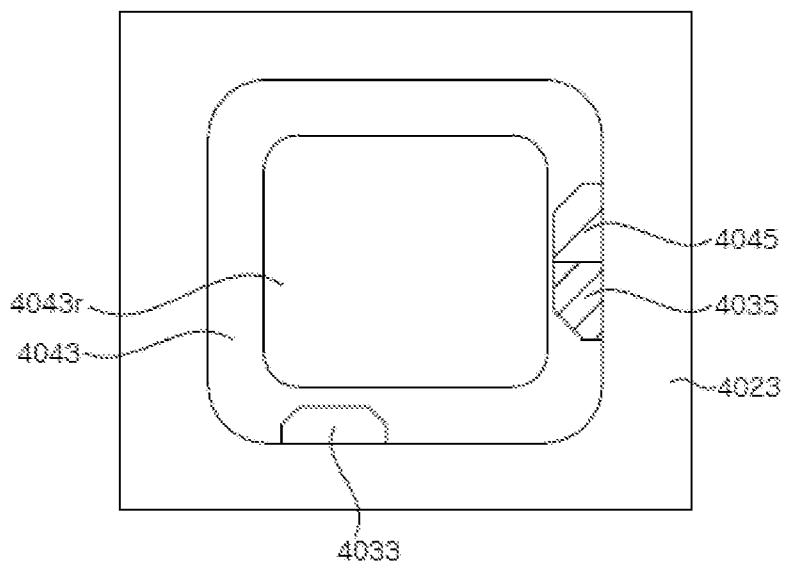


FIG. 79F

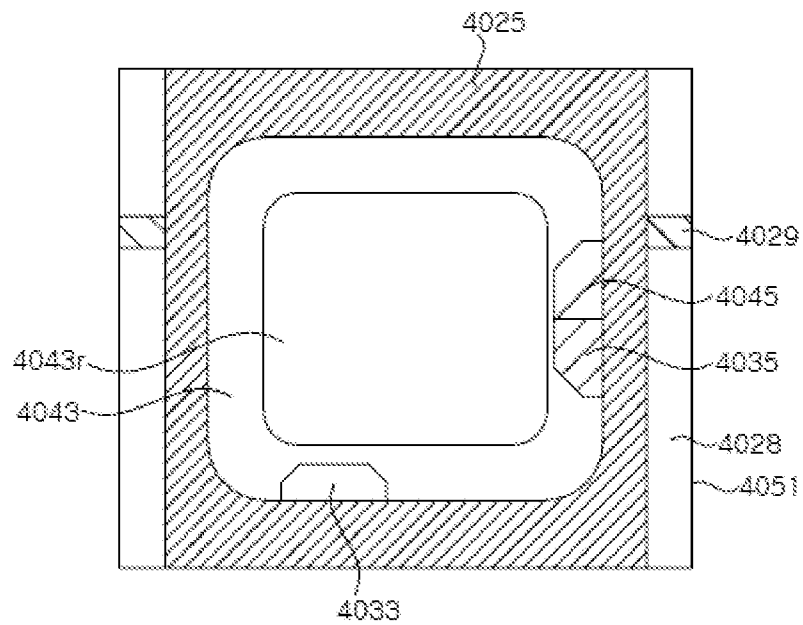


FIG. 79G

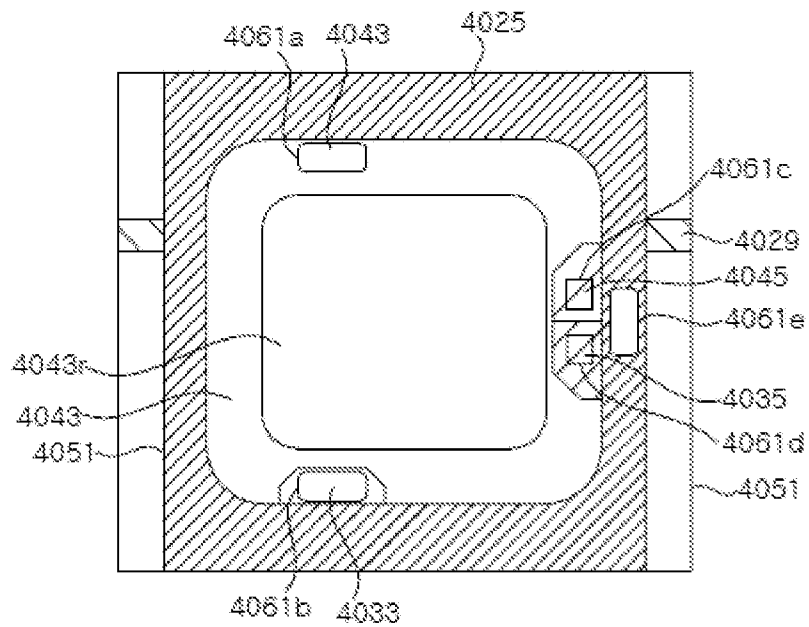


FIG. 79H

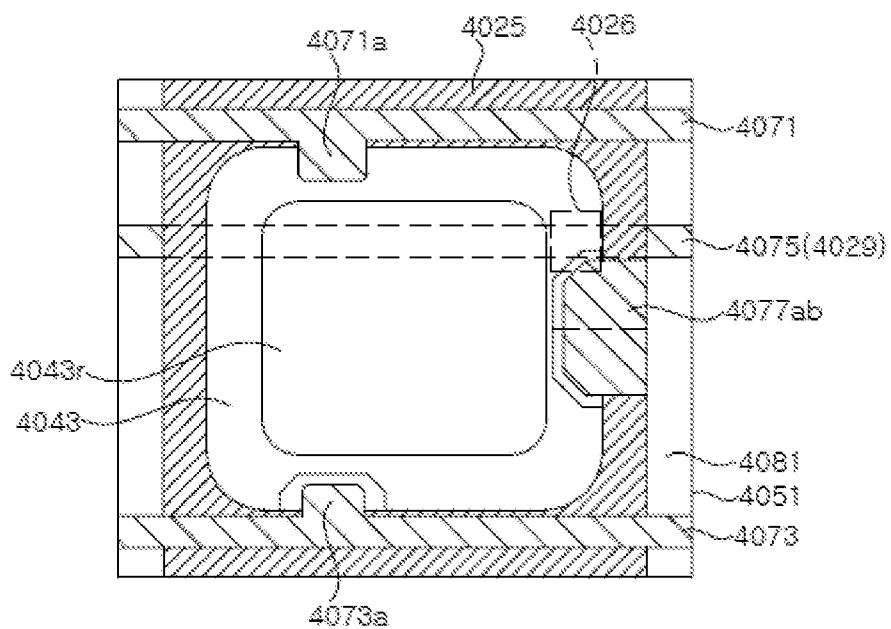


FIG. 80

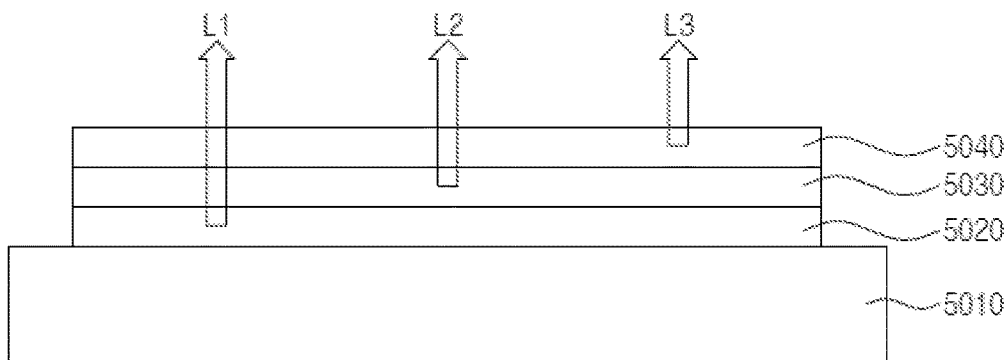


FIG. 81A

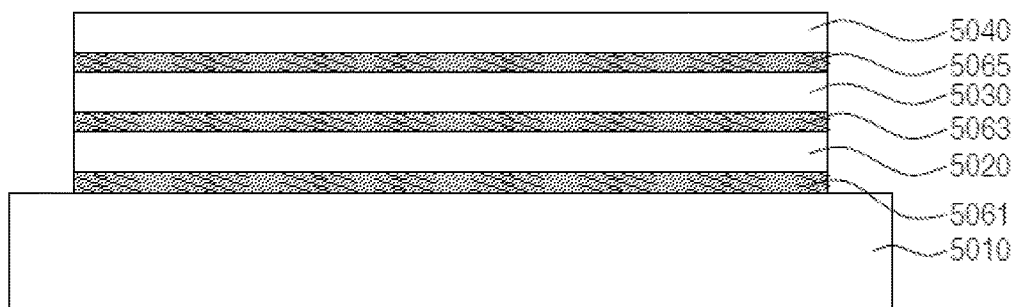


FIG. 81B

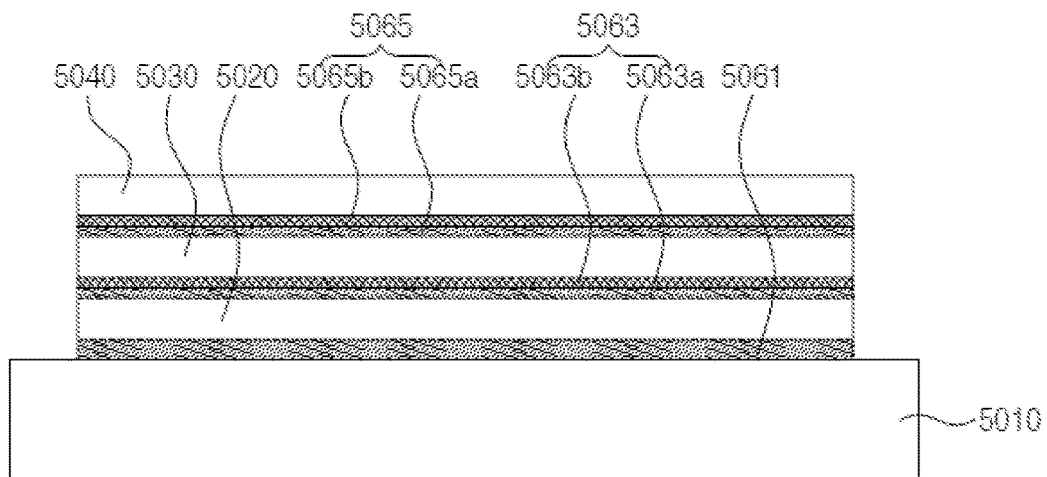


FIG. 82

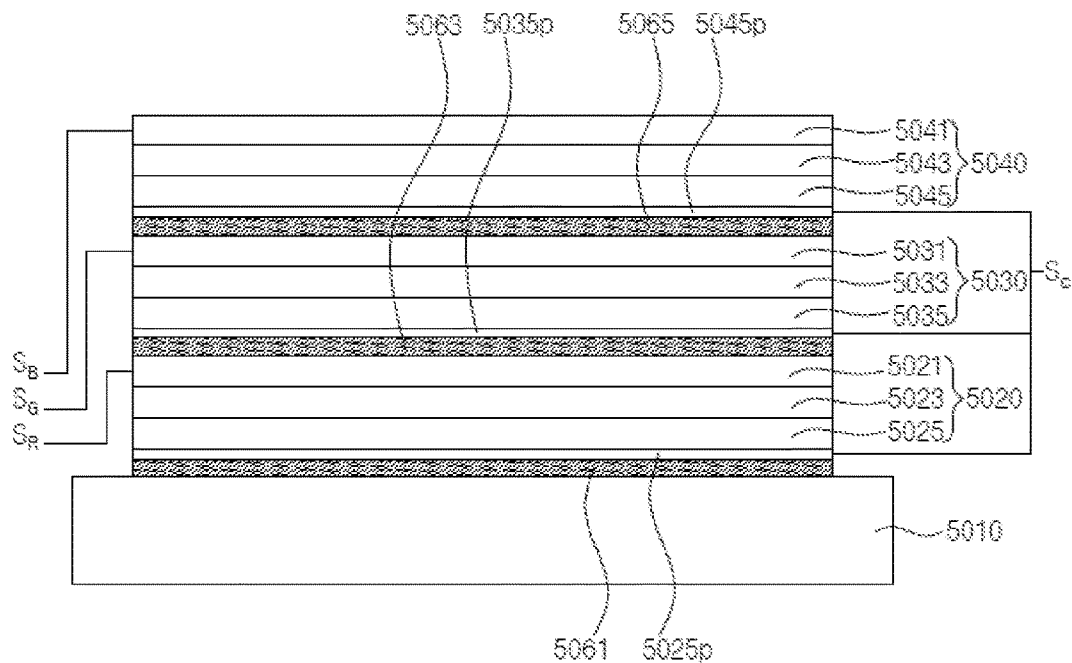


FIG. 83

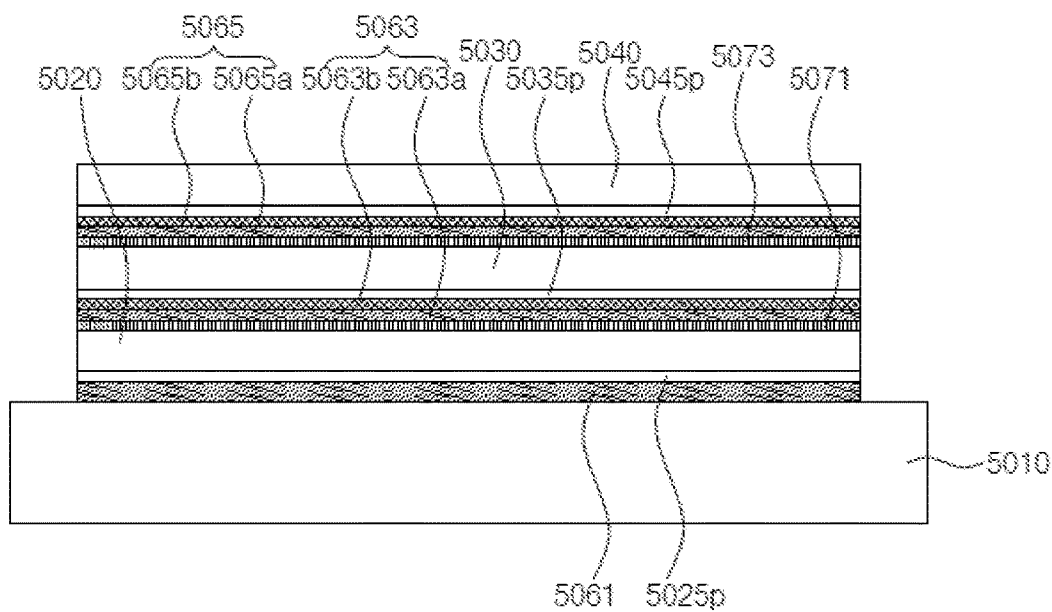


FIG. 84

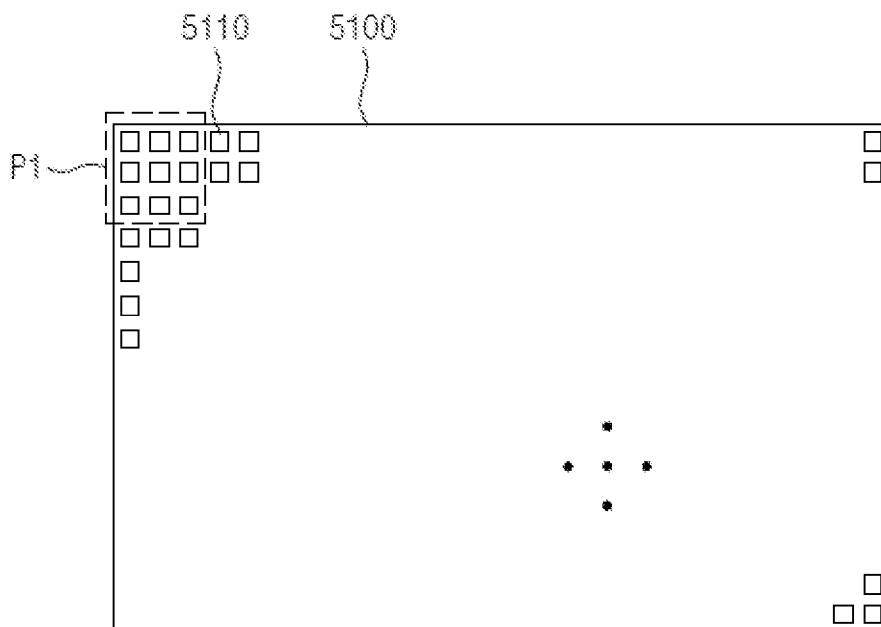


FIG. 85

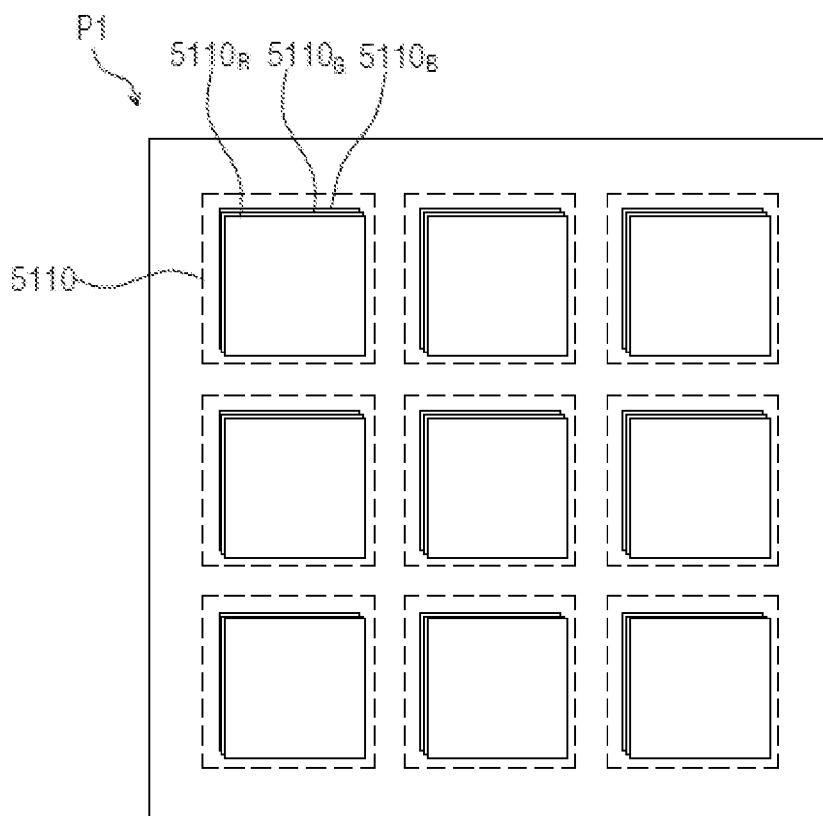


FIG. 86

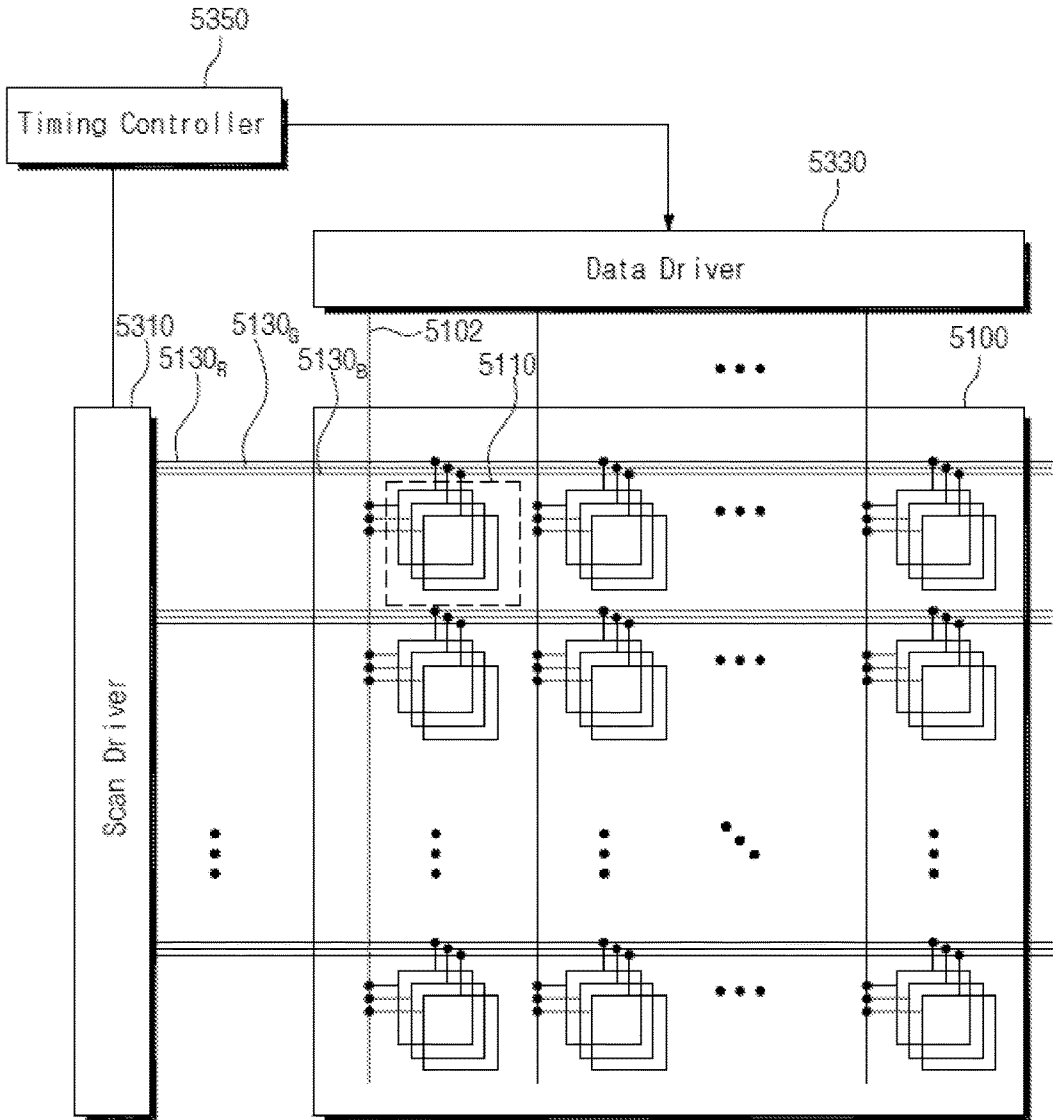


FIG. 87

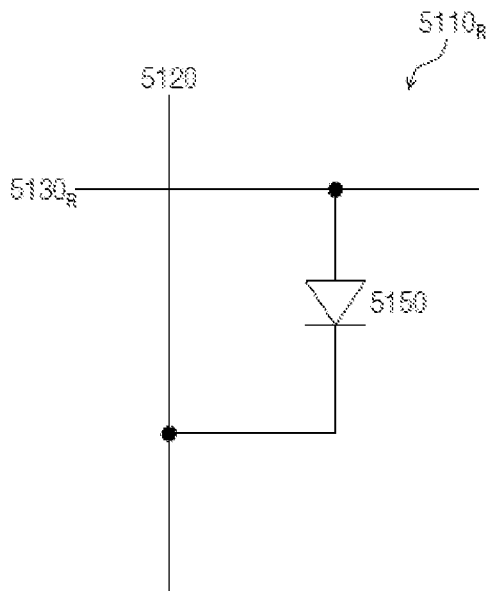


FIG. 88

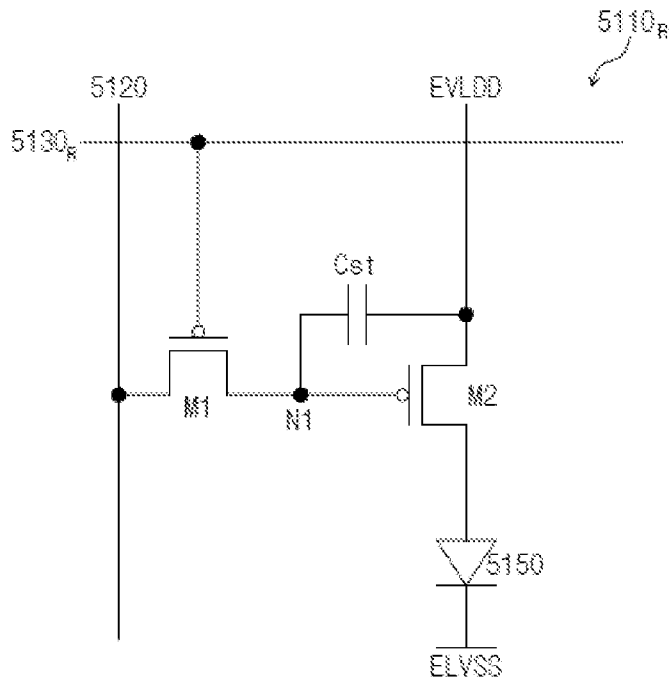


FIG. 89

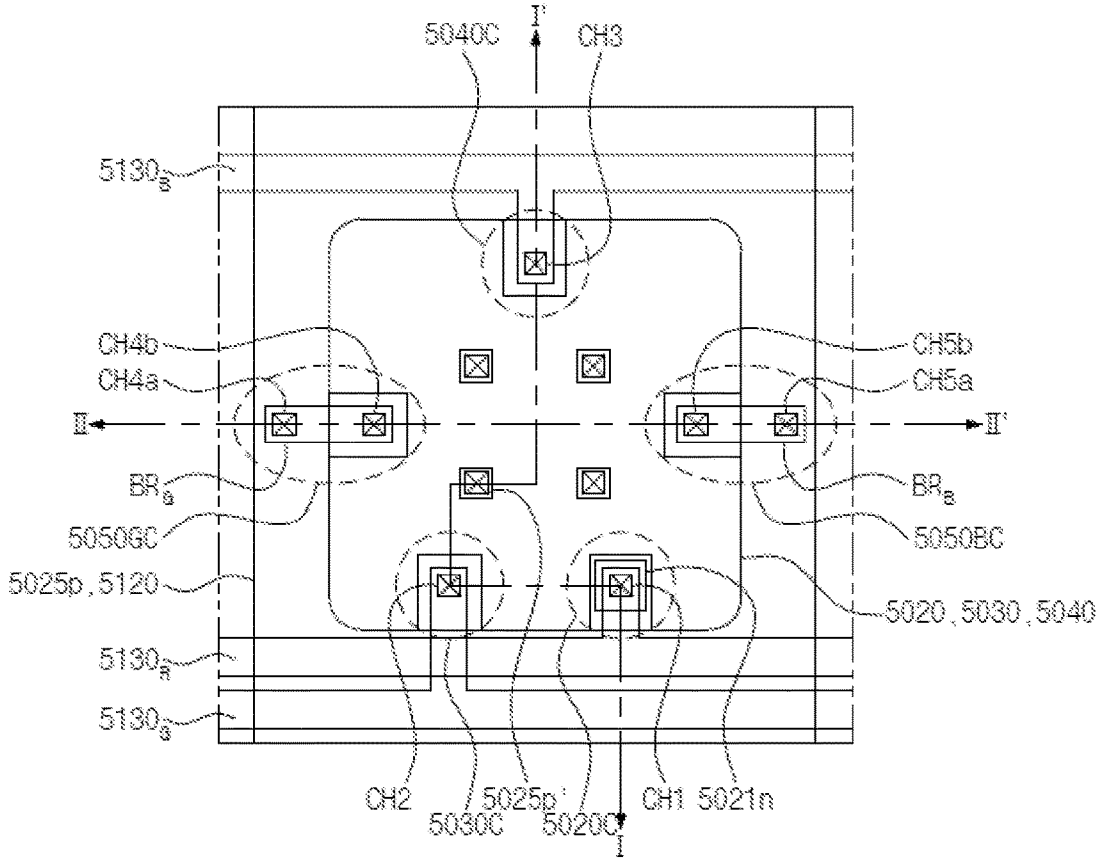


FIG. 90A

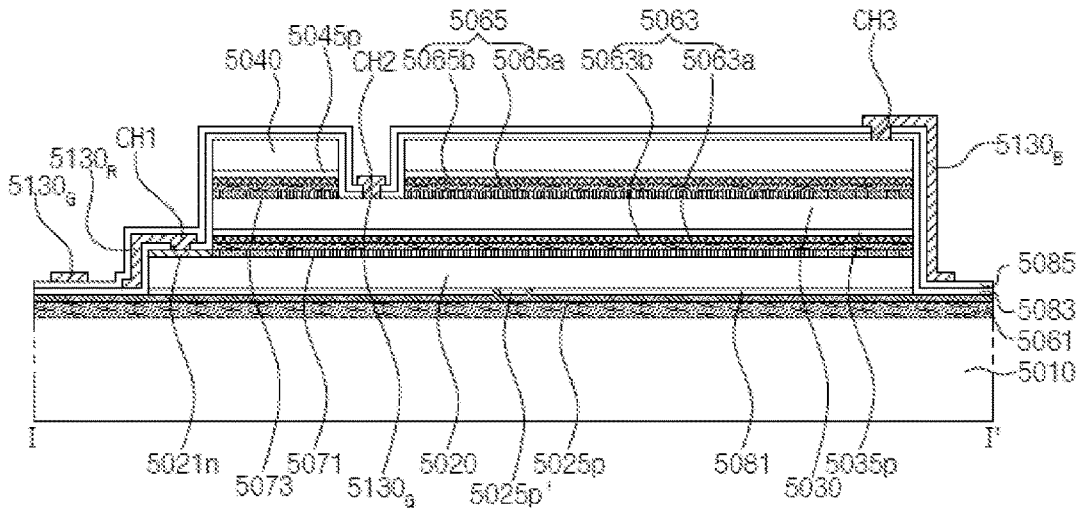


FIG. 90B

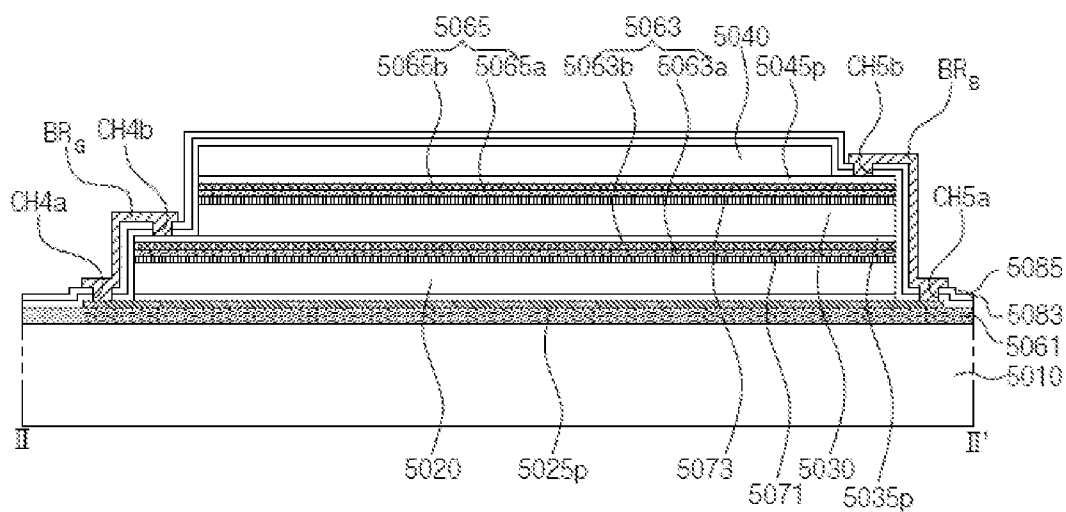


FIG. 91A

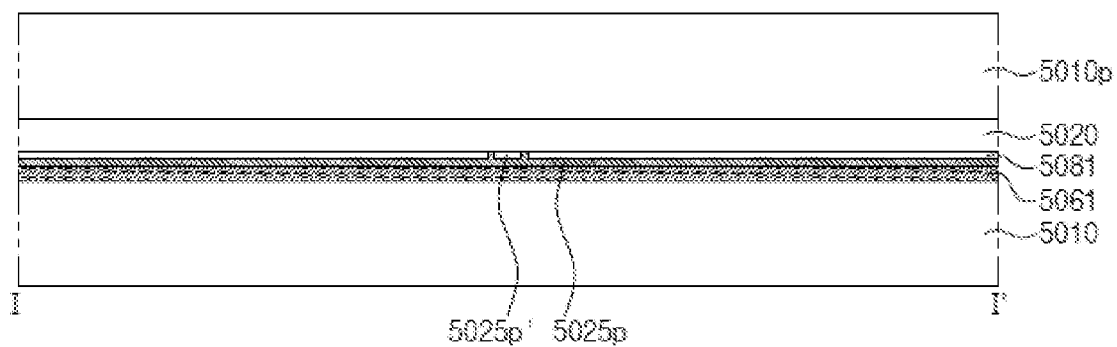


FIG. 91B

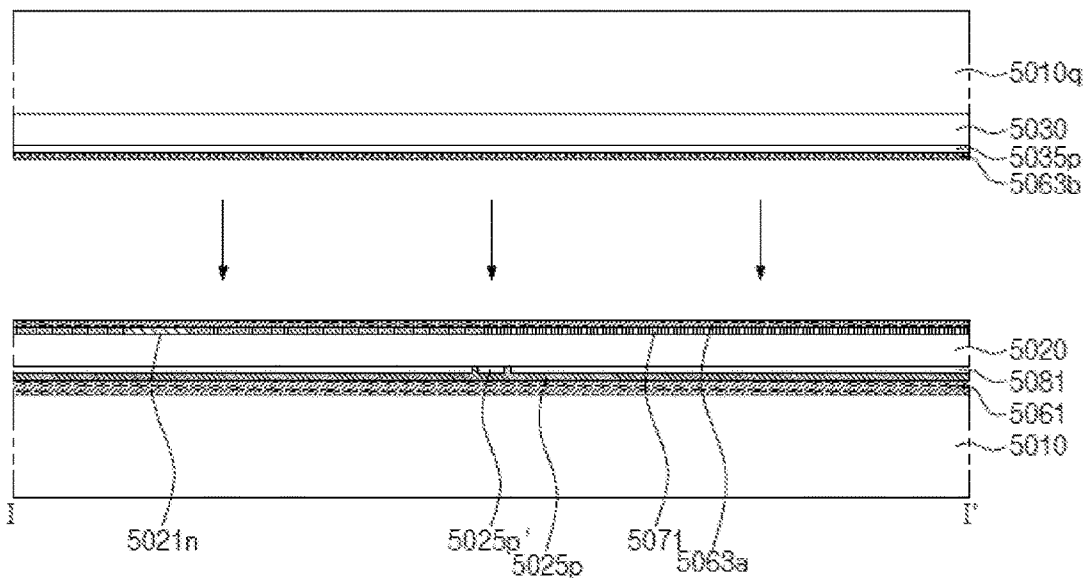


FIG. 91C

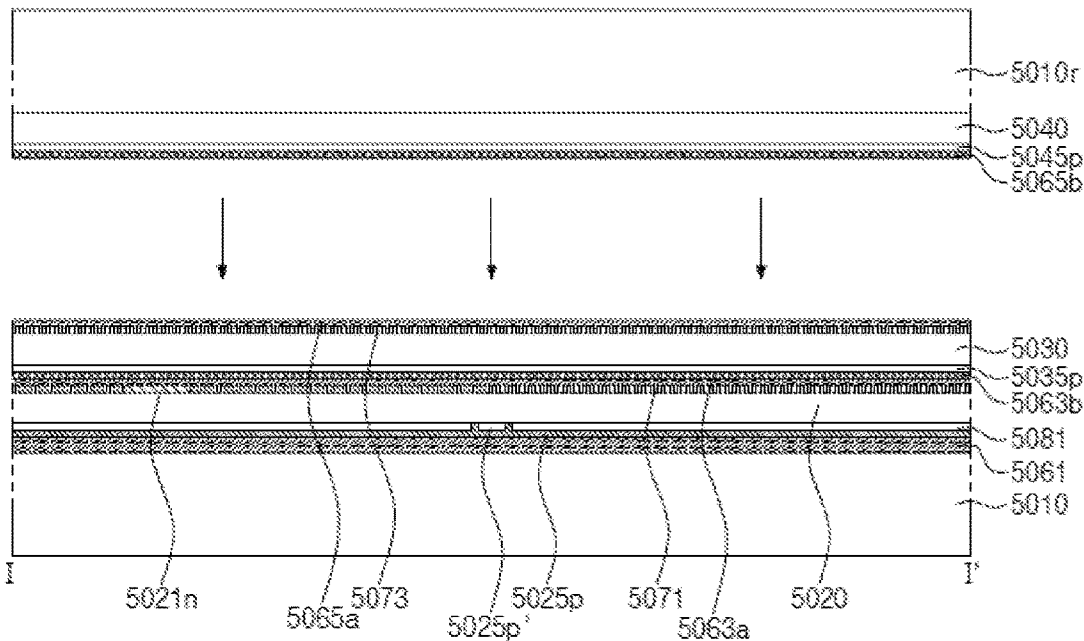


FIG. 92

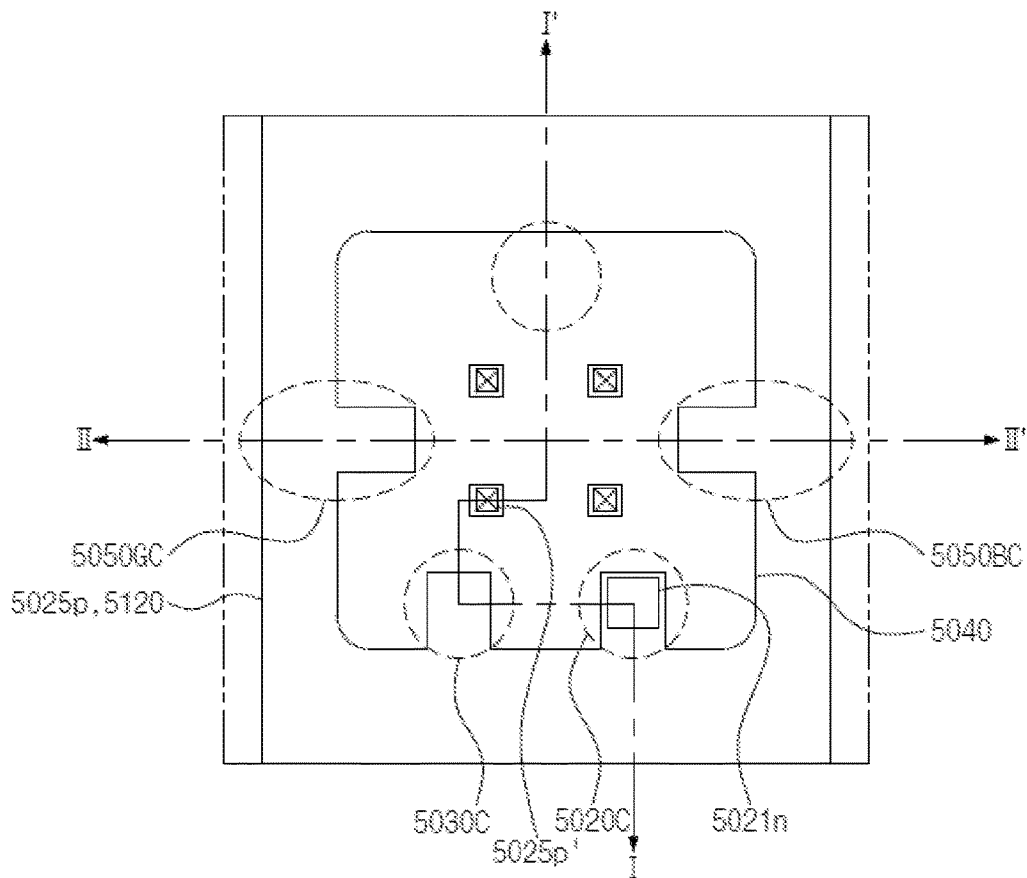


FIG. 93A

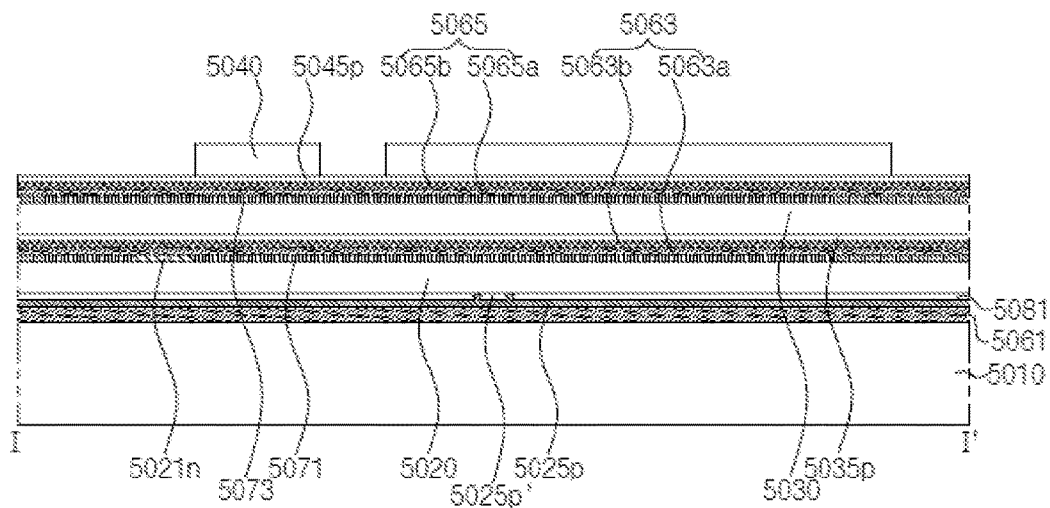


FIG. 93B

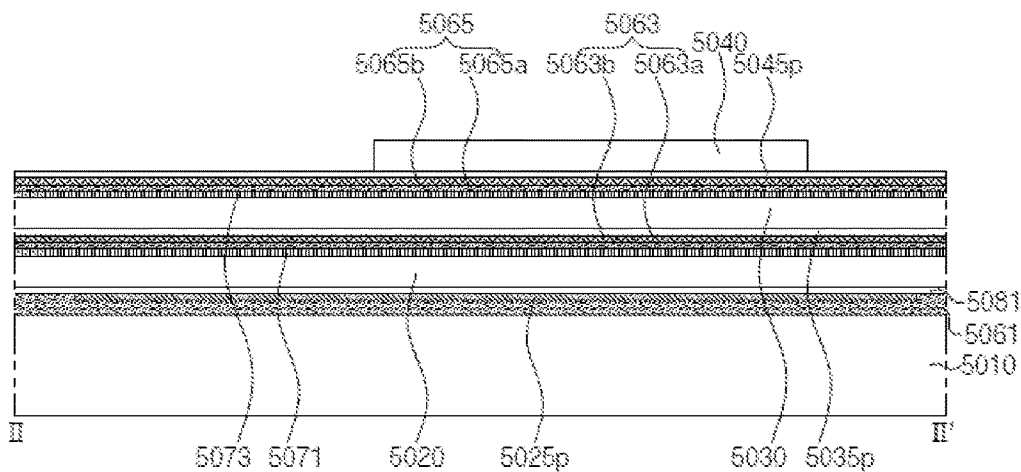


FIG. 94

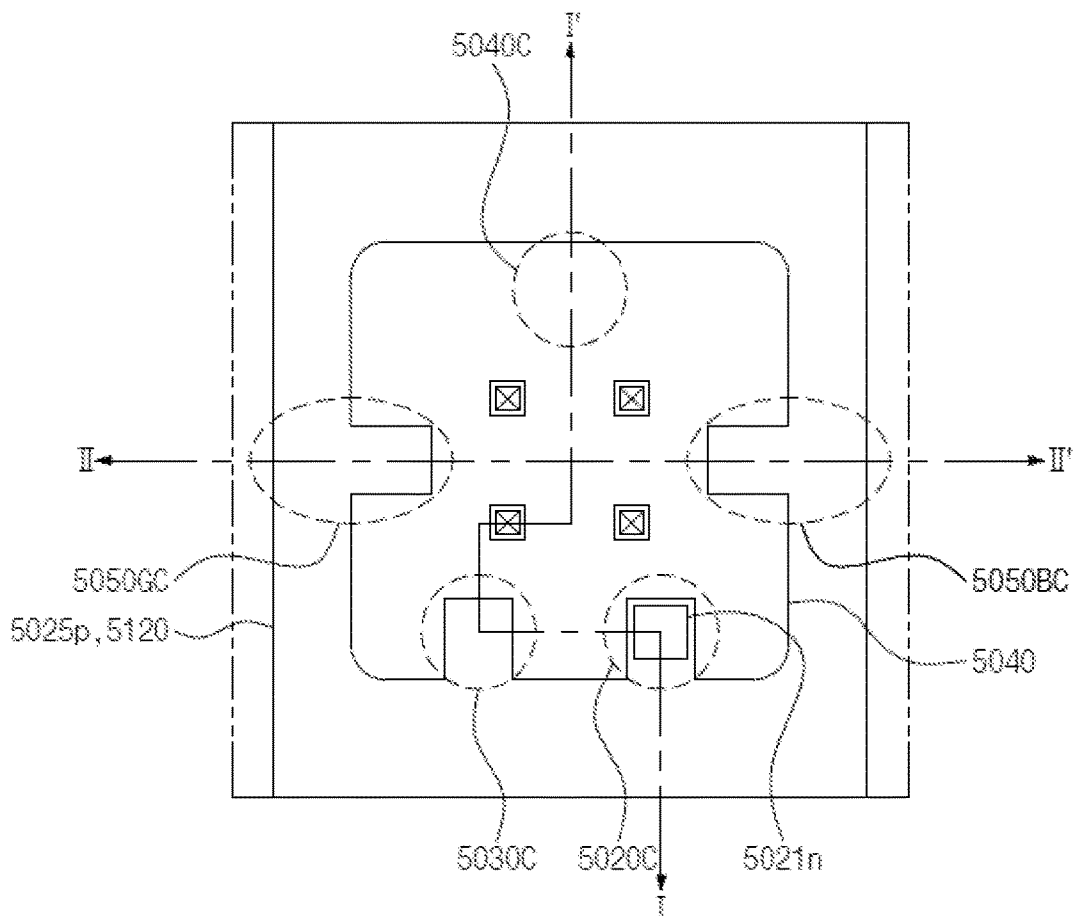


FIG. 95A

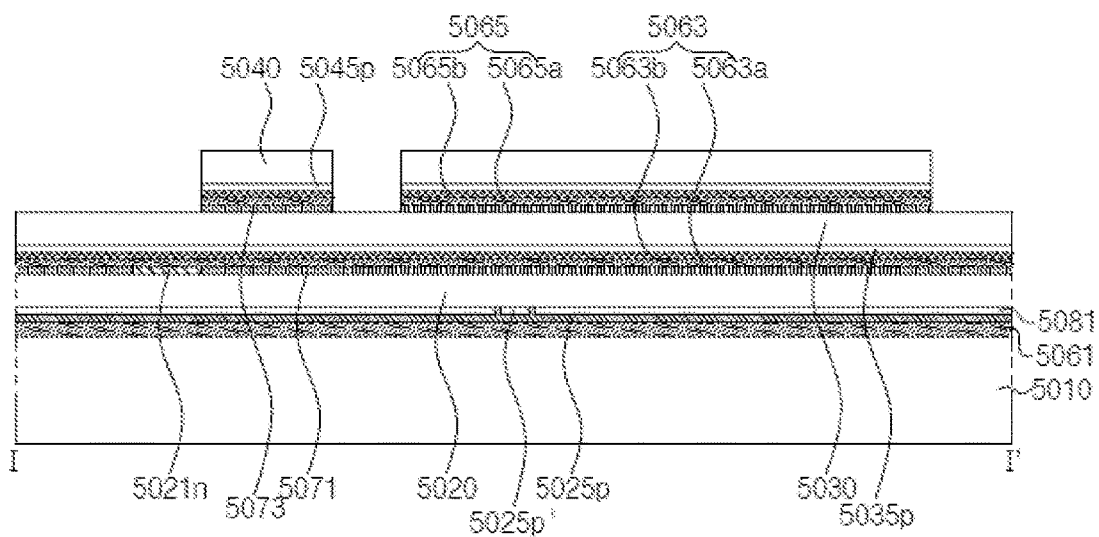


FIG. 95B

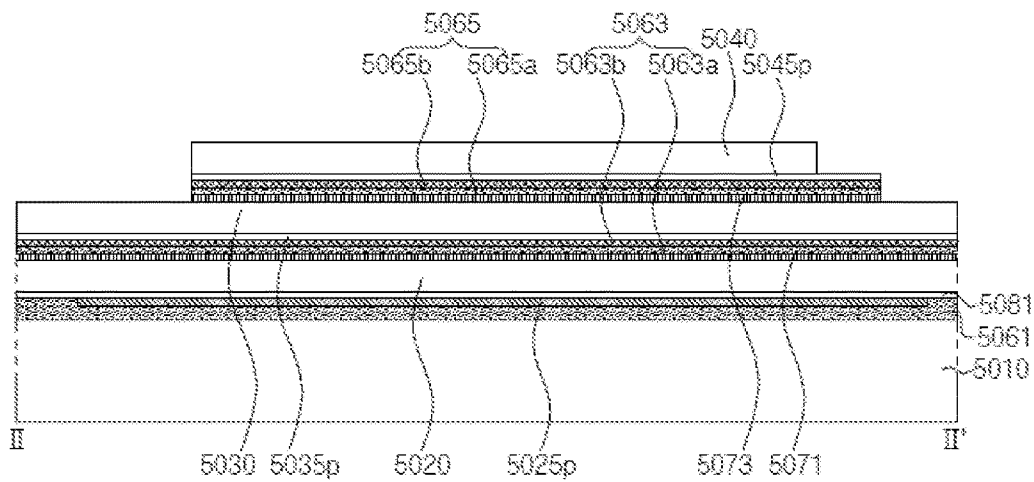


FIG. 96

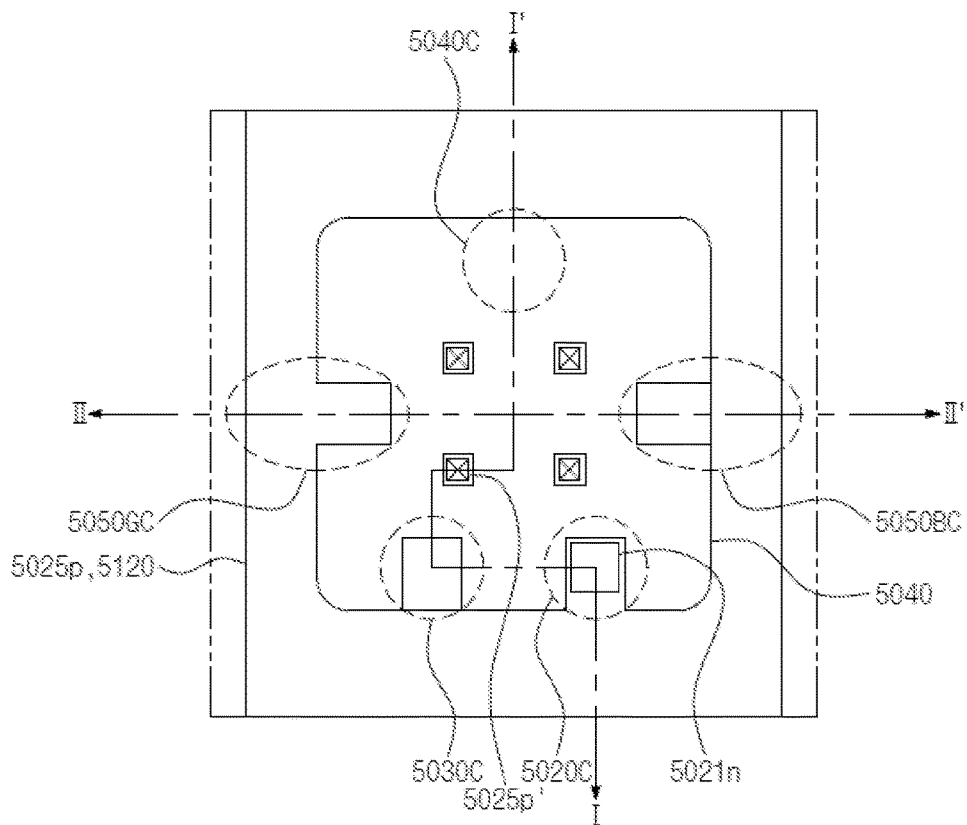


FIG. 97A

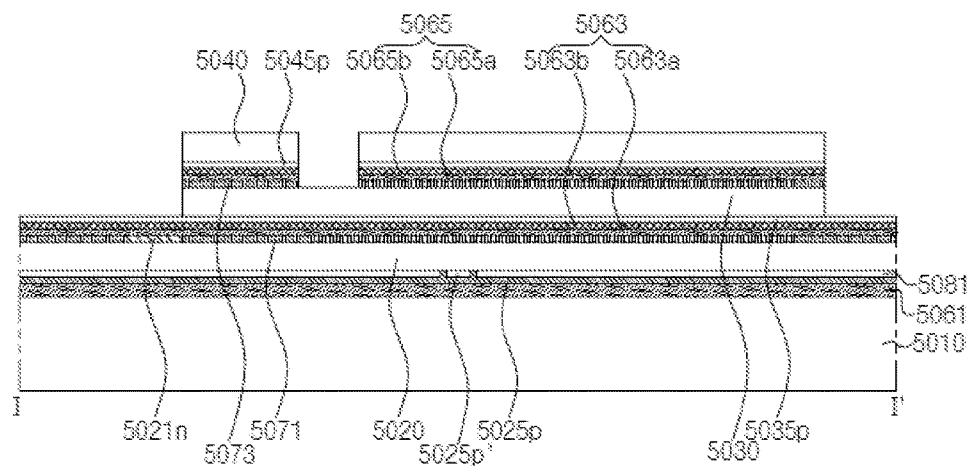


FIG. 97B

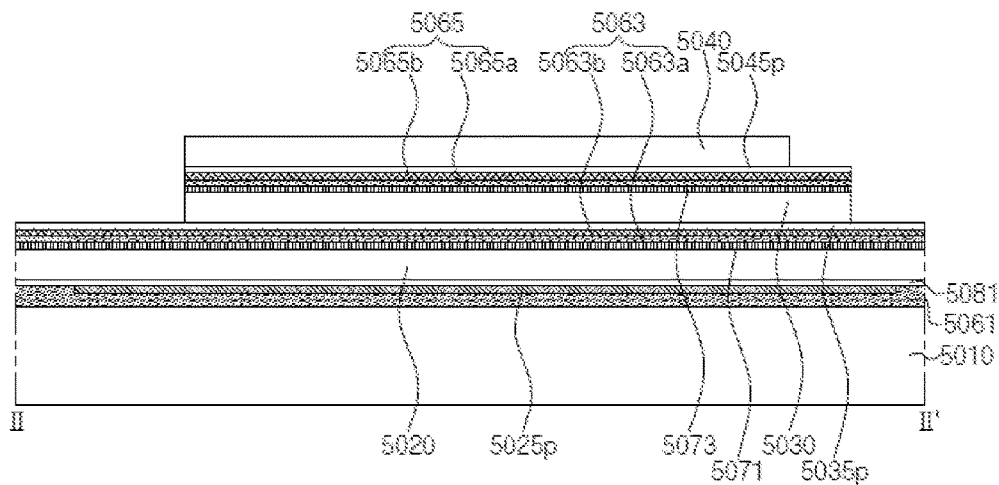


FIG. 98

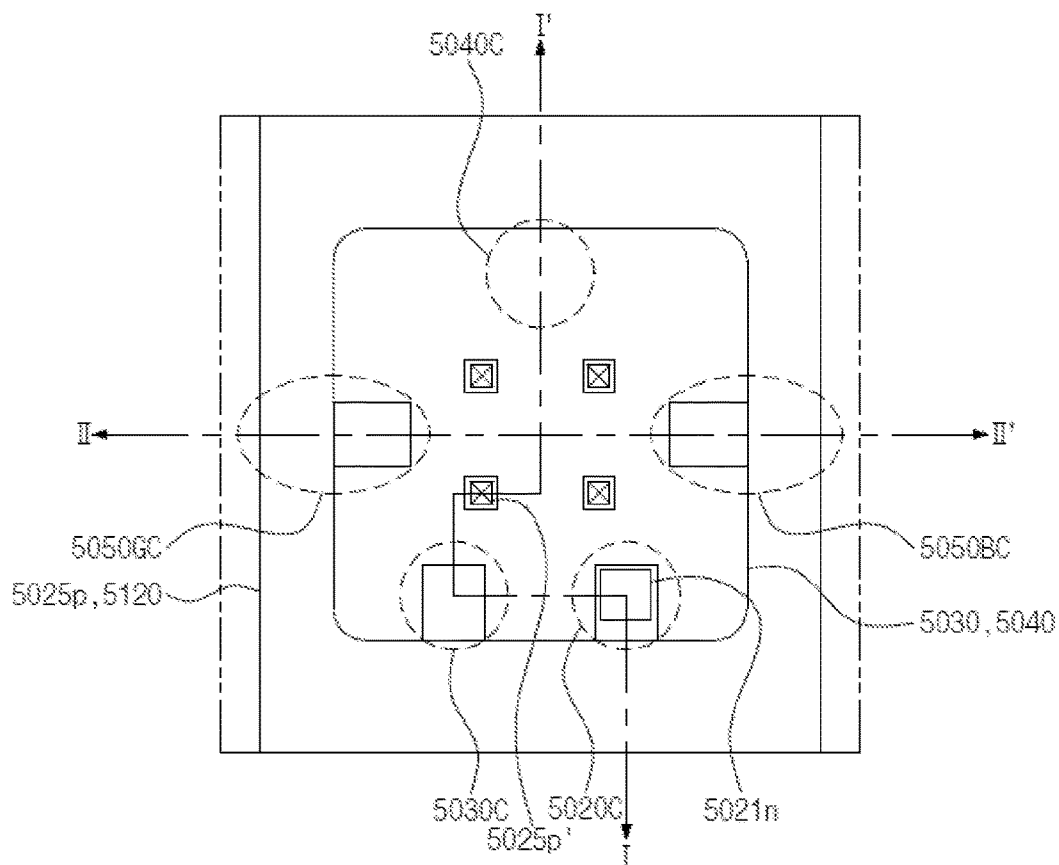


FIG. 99A

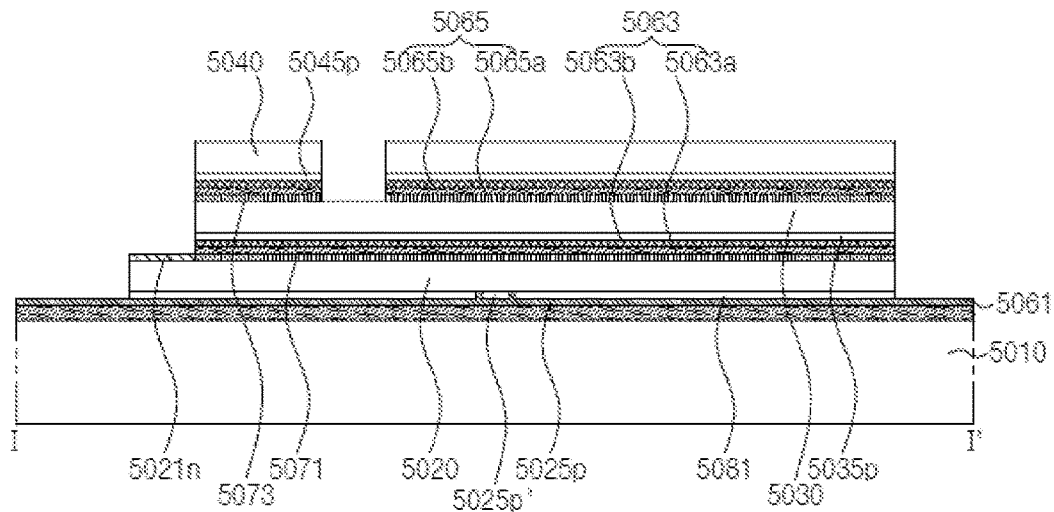


FIG. 99B

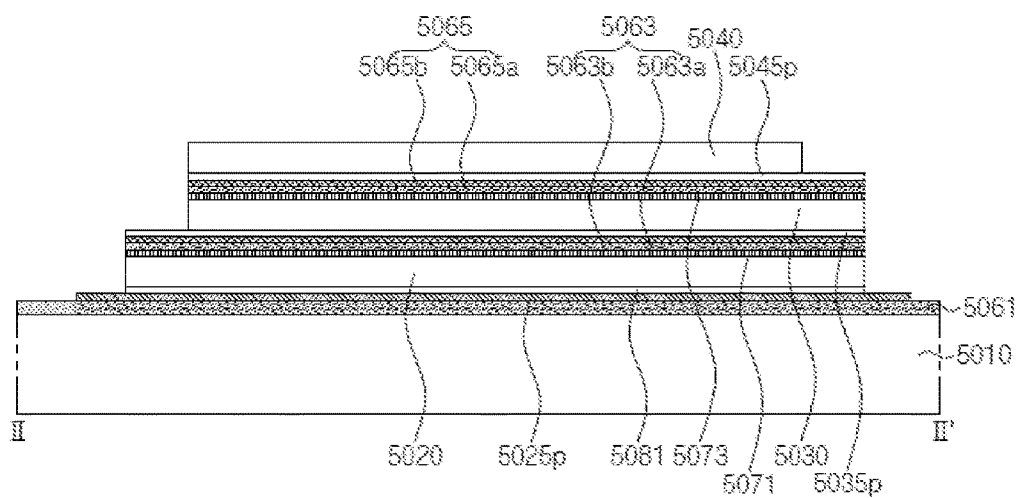


FIG. 100

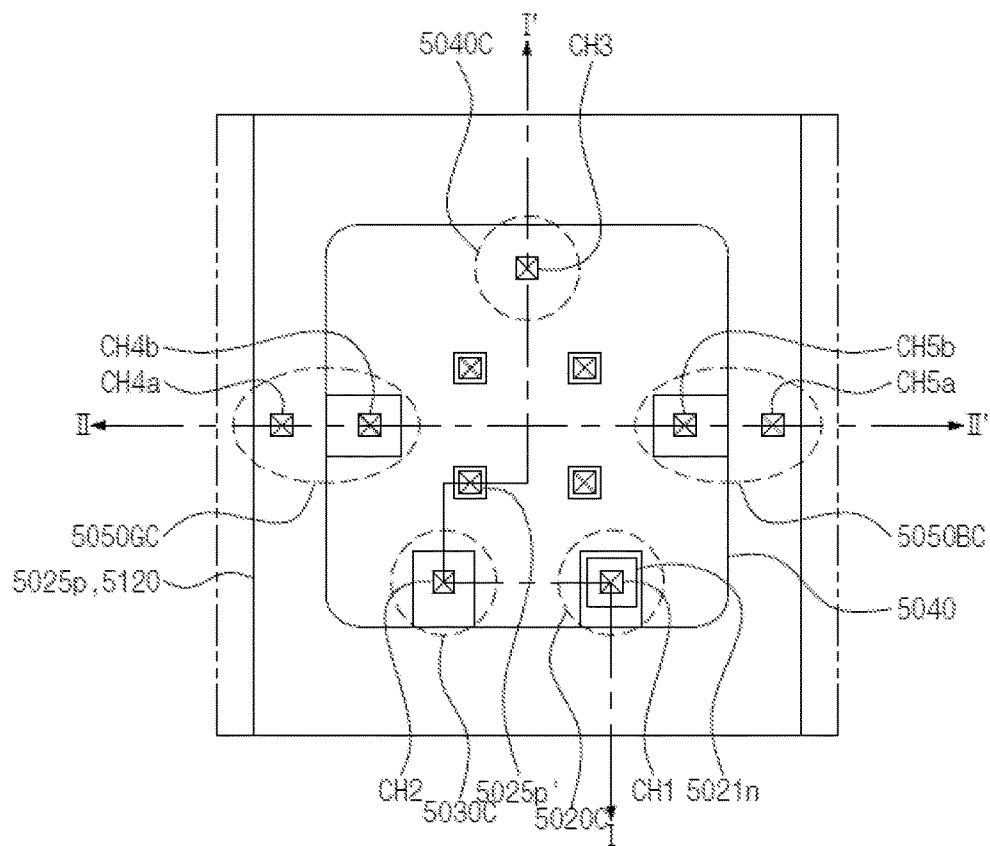


FIG. 101A

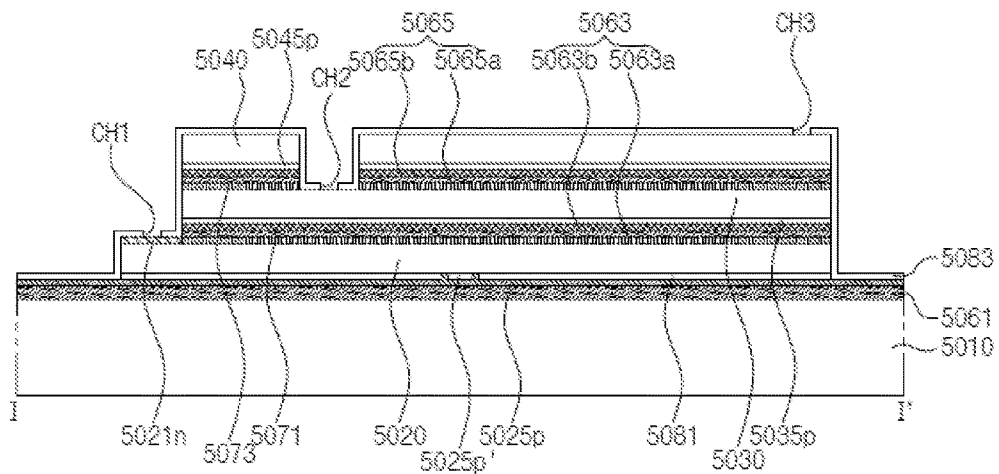


FIG. 101B

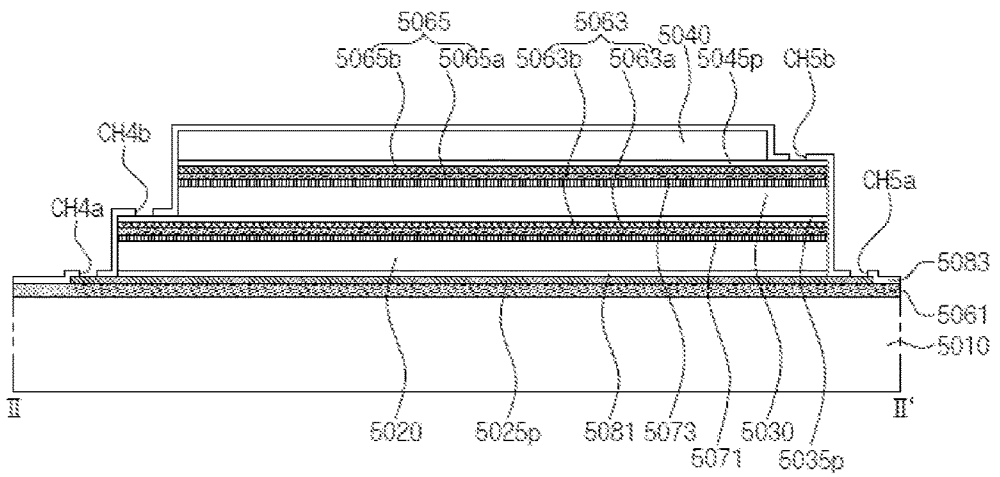


FIG. 102

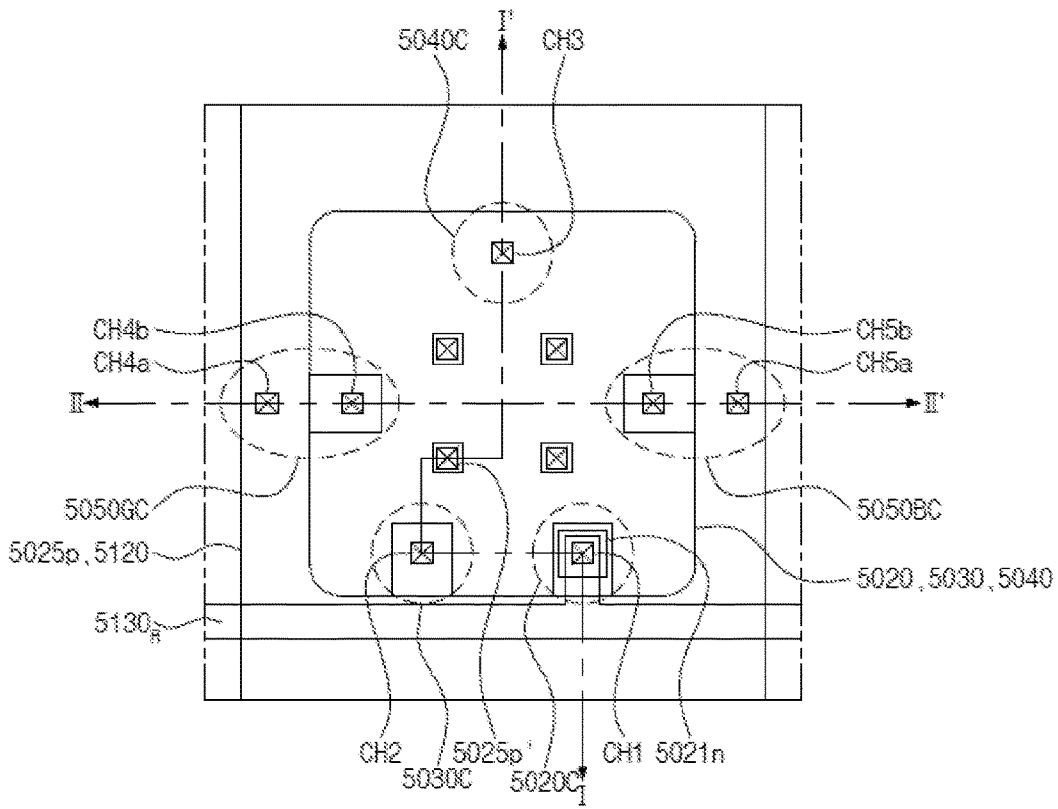


FIG. 103A

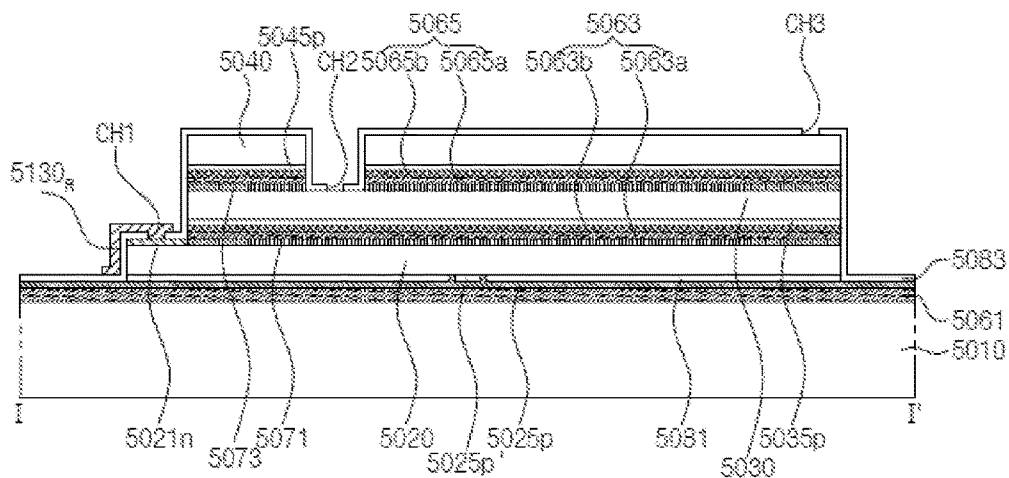


FIG. 103B

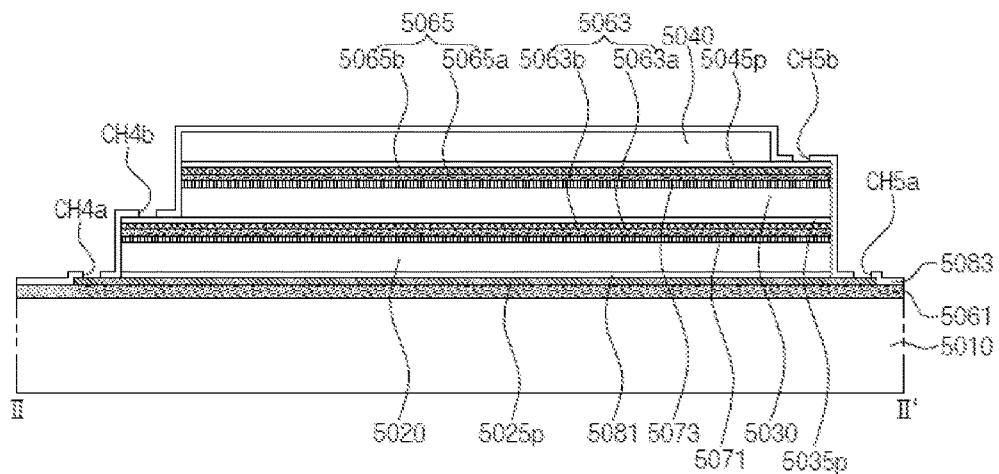


FIG. 104

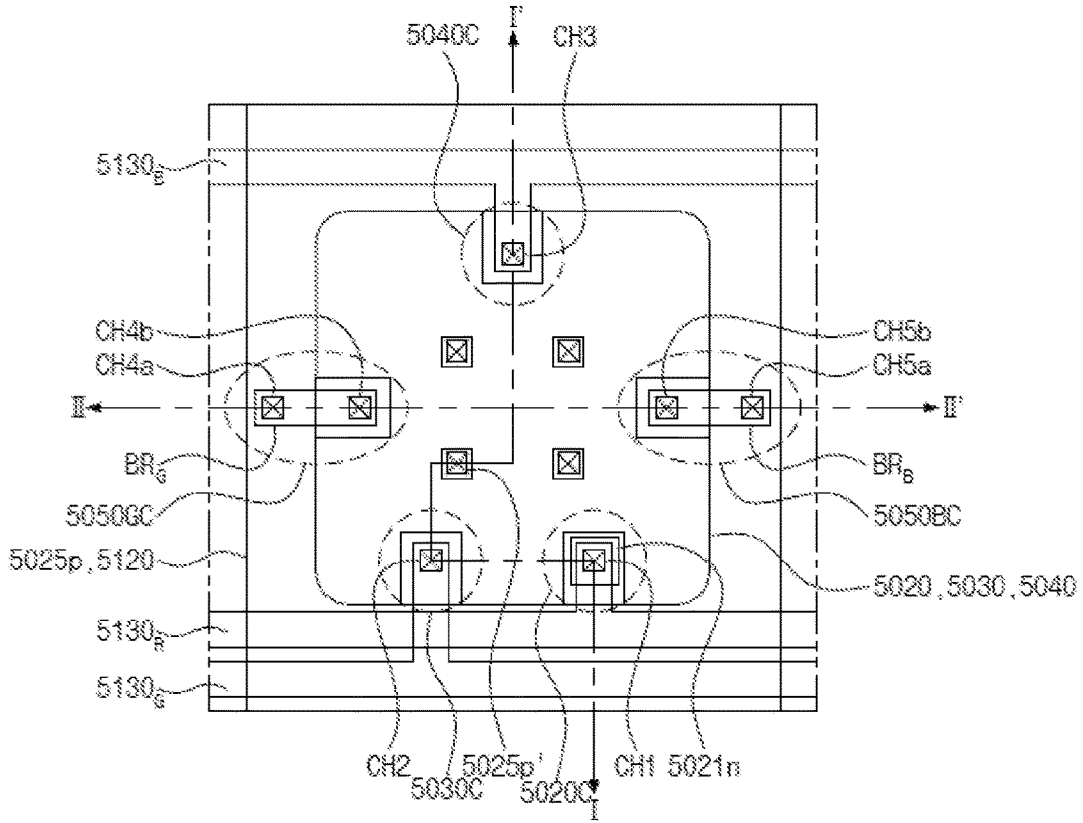


FIG. 105A

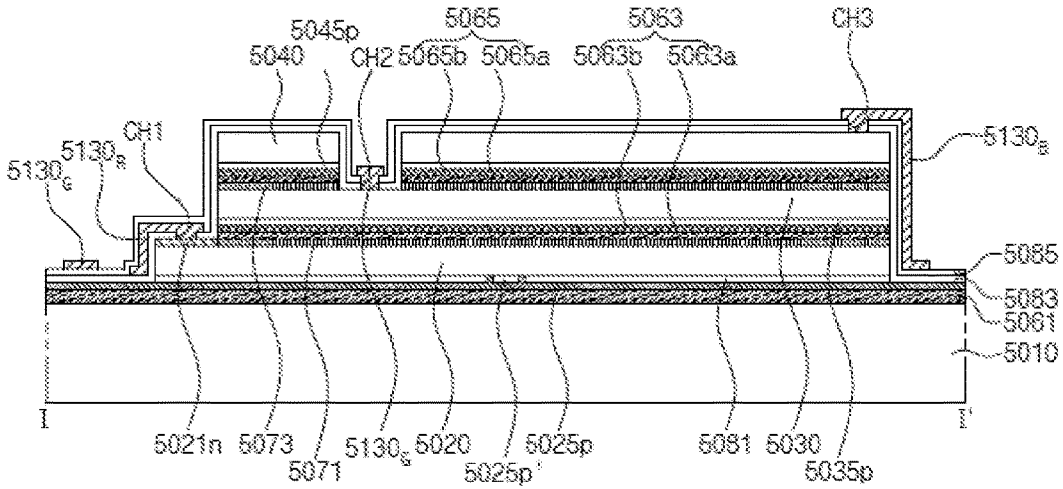


FIG. 105B

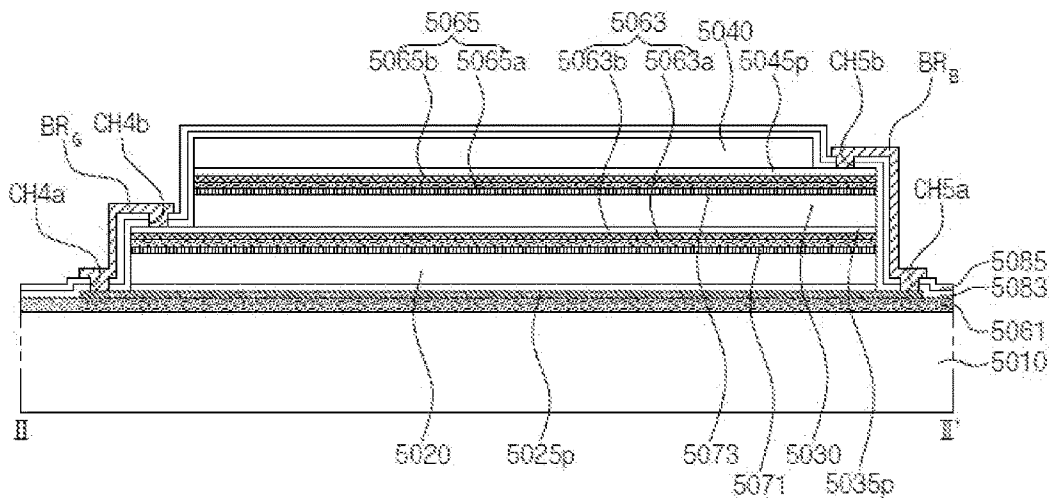


FIG. 106

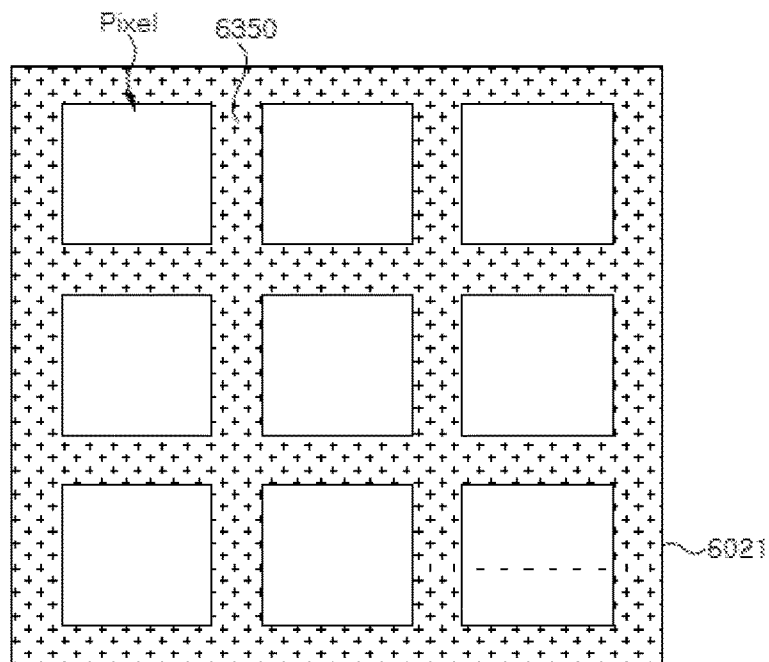


FIG. 107A

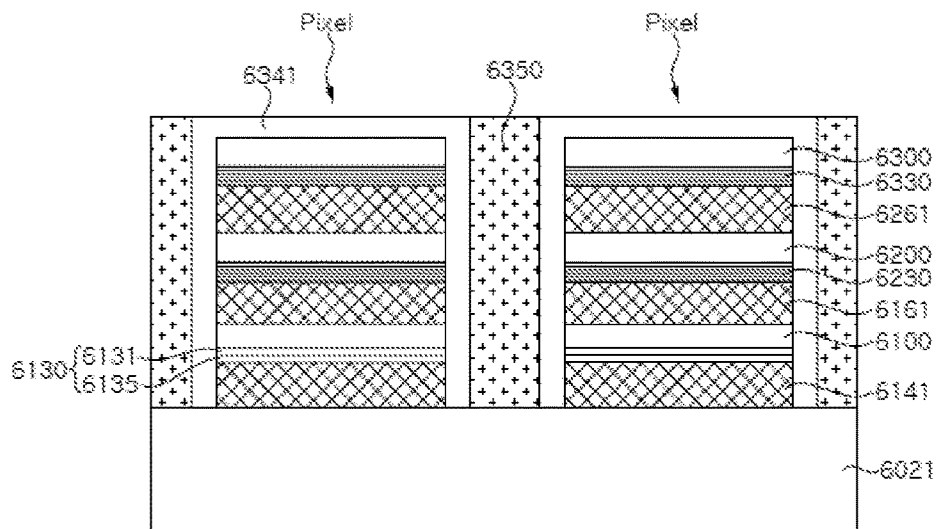


FIG. 107B

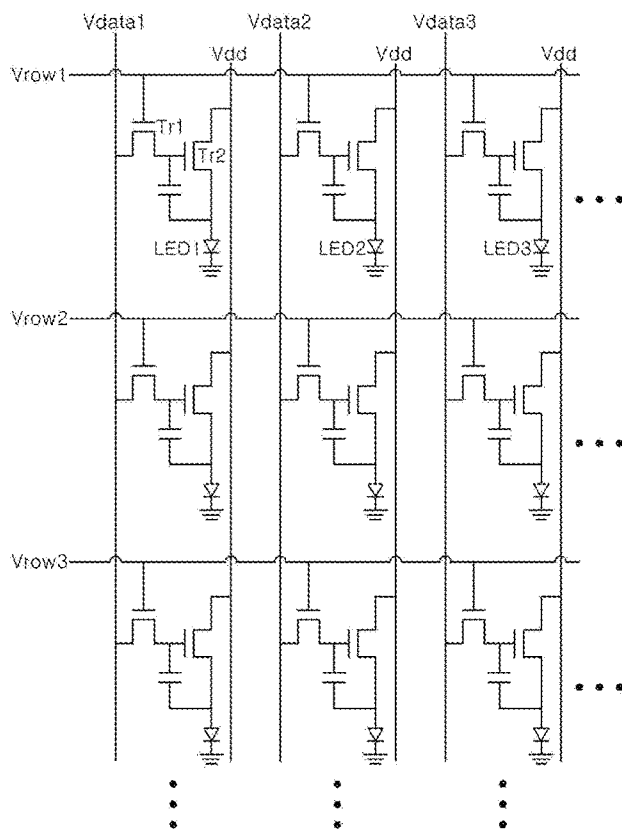


FIG. 108A

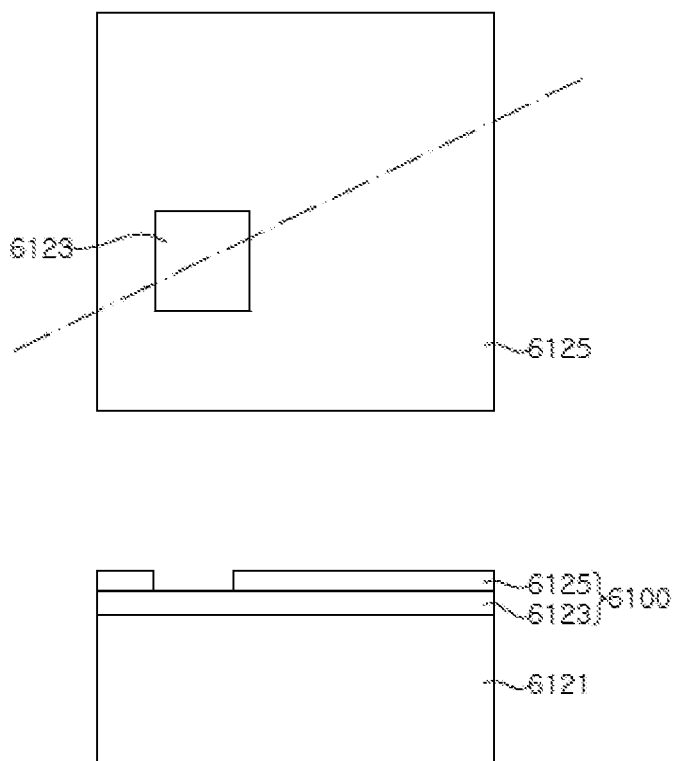


FIG. 108B

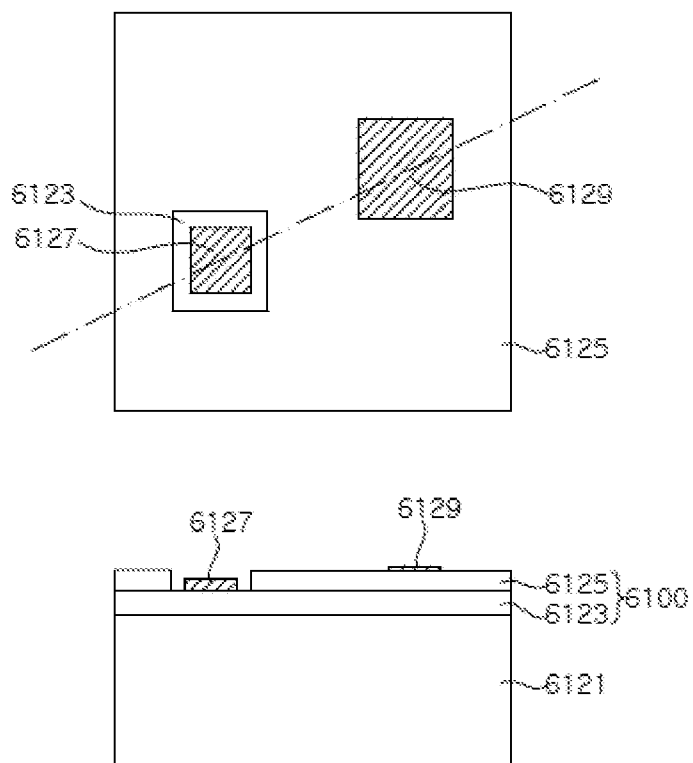


FIG. 108C

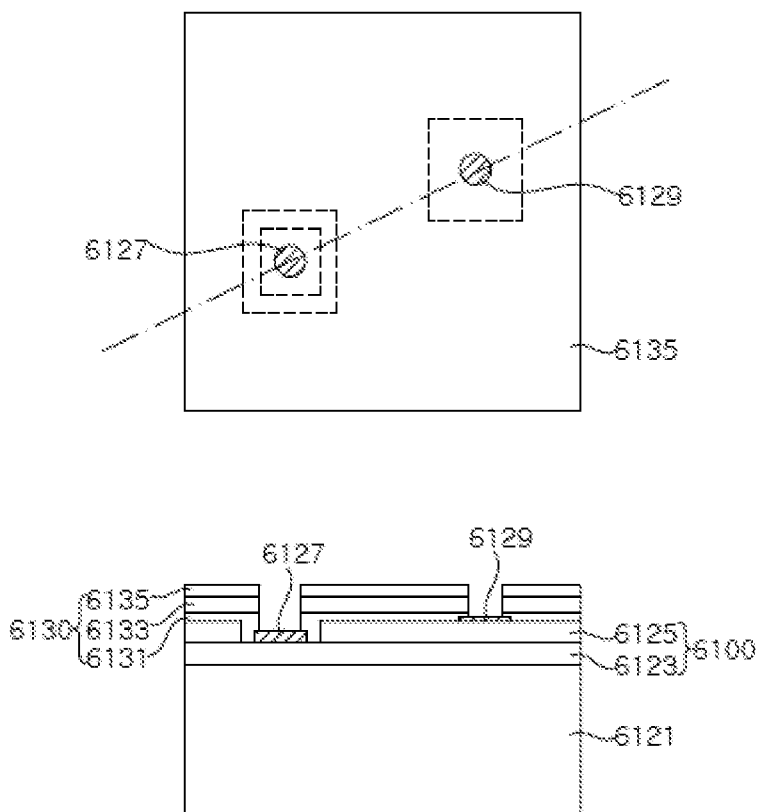


FIG. 108D

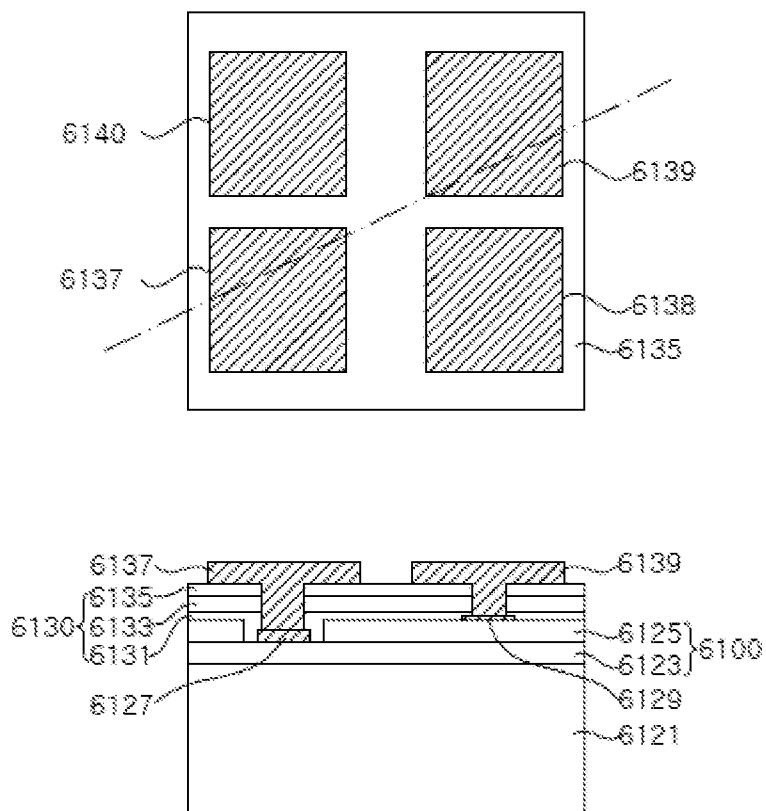


FIG. 108E

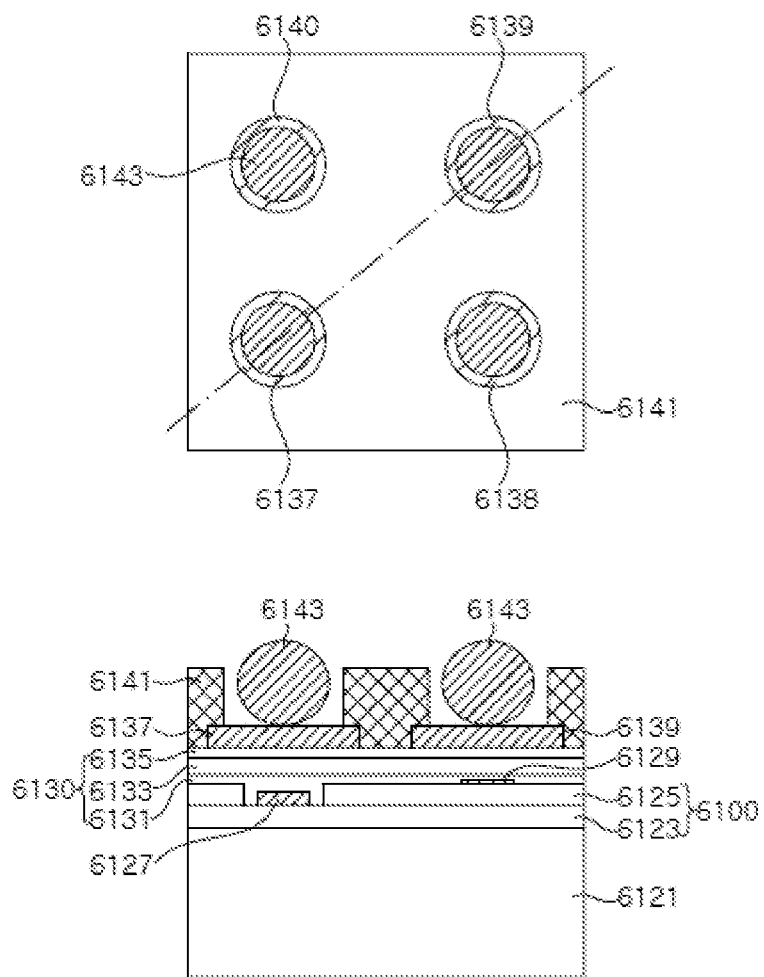


FIG. 109A

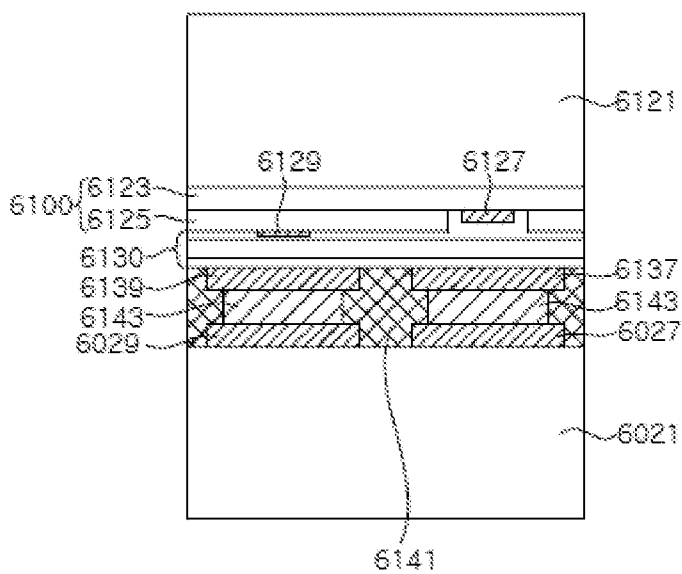
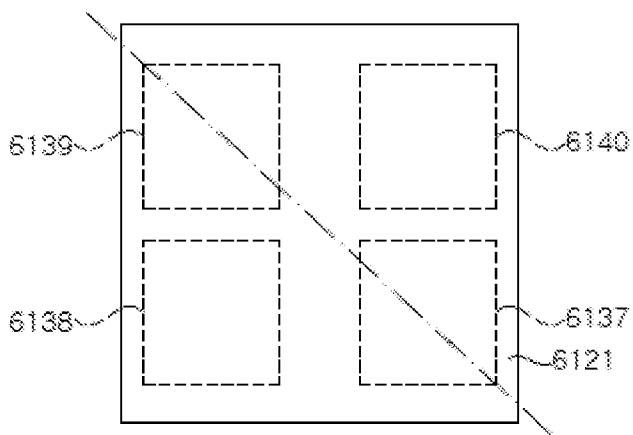


FIG. 109B

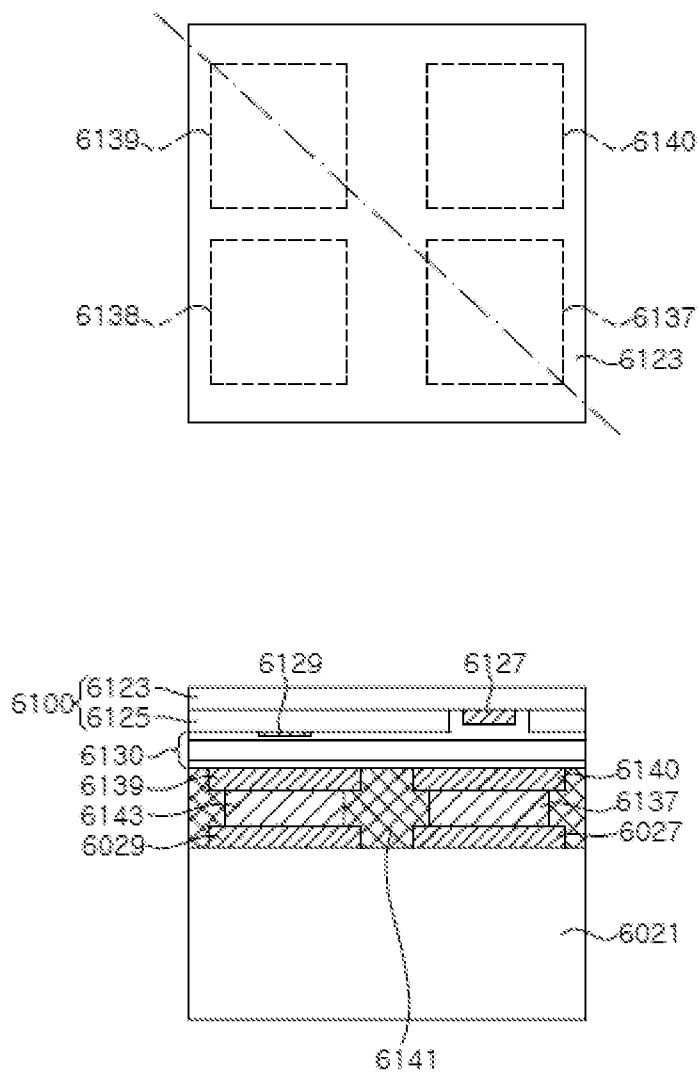


FIG. 109C

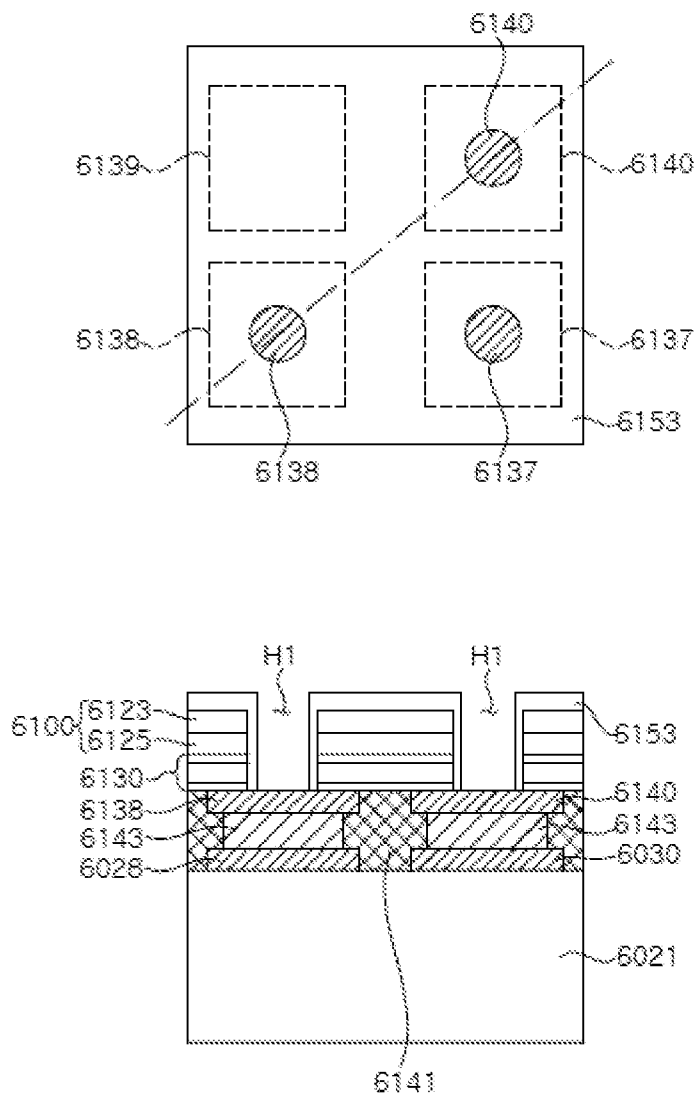


FIG. 109D

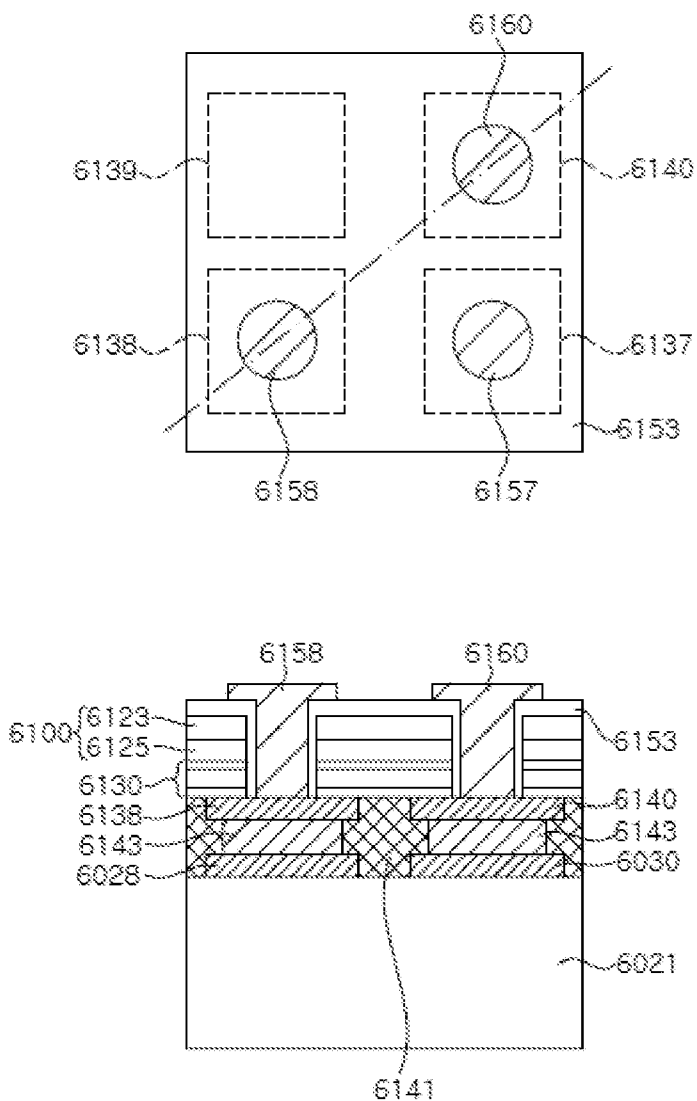


FIG. 109E

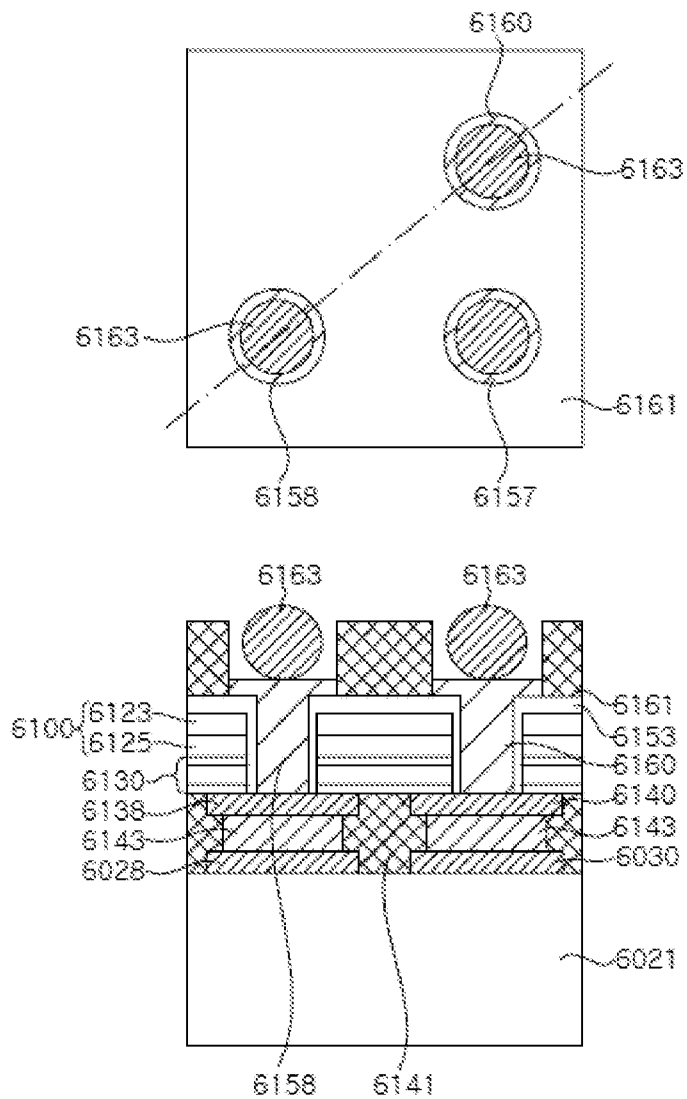


FIG. 110A

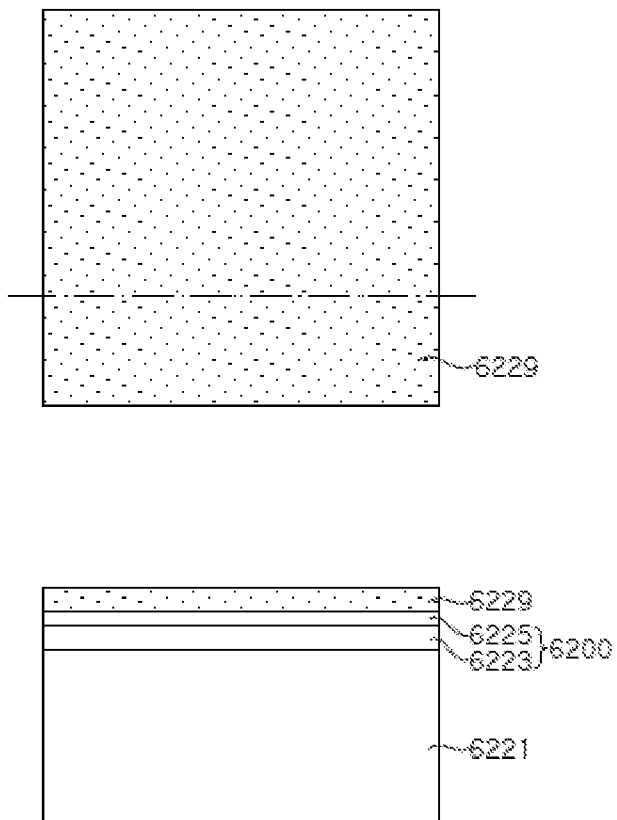


FIG. 110B

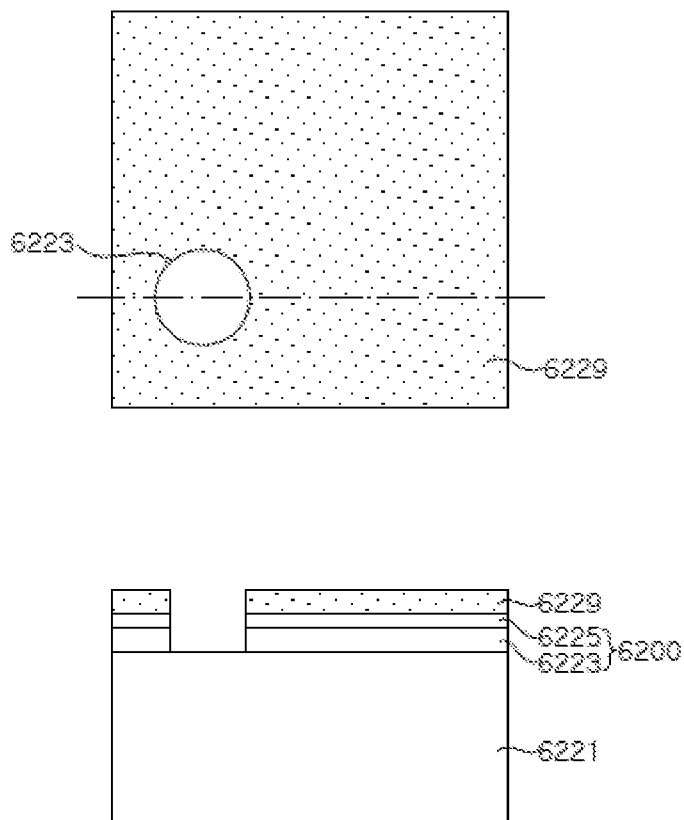


FIG. 110C

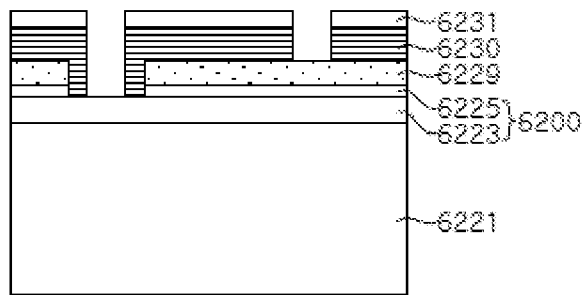
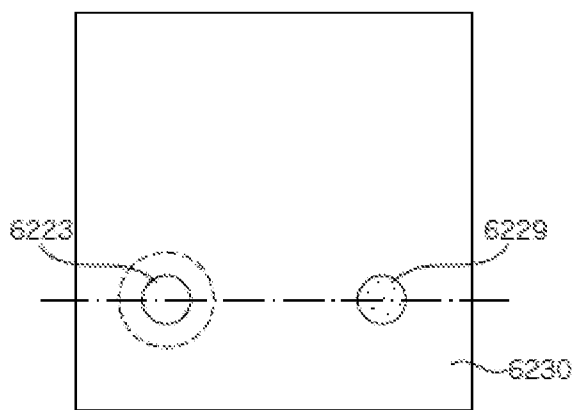


FIG. 110D

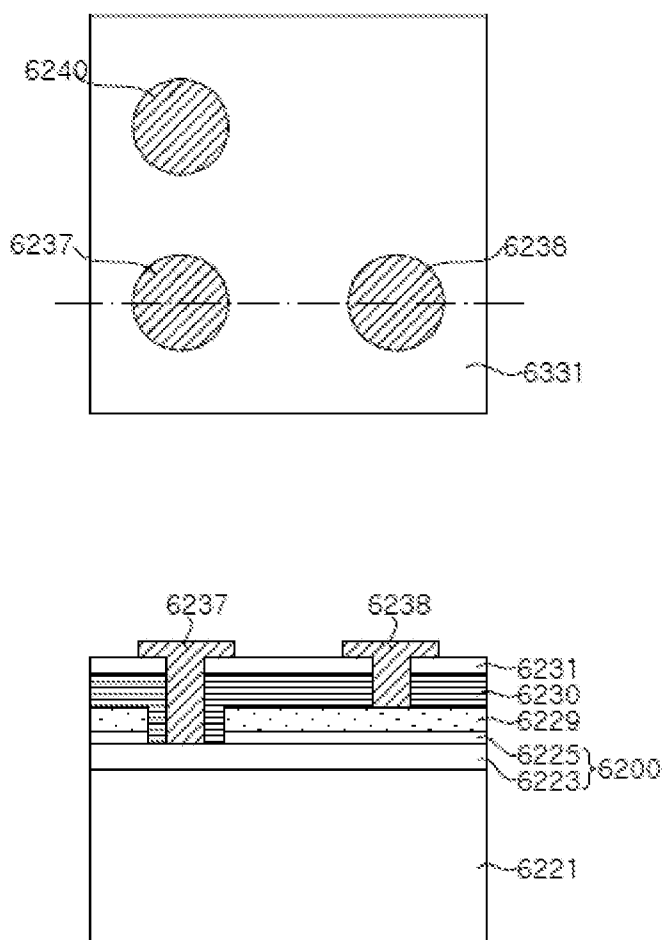


FIG. 111A

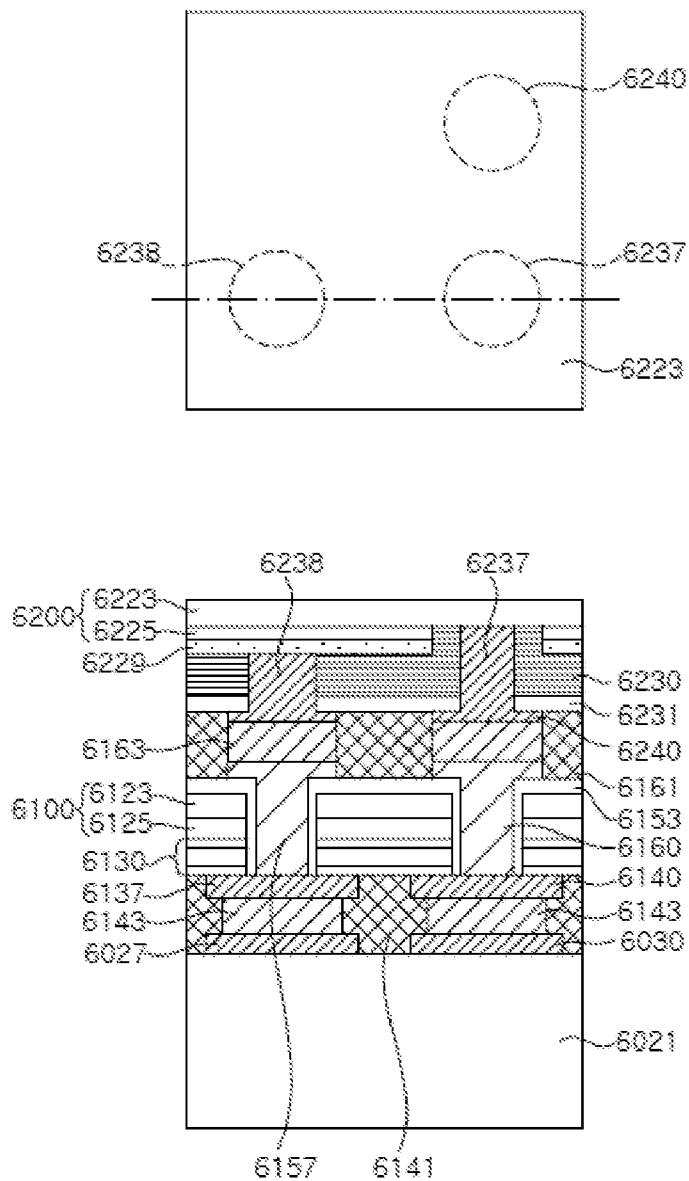


FIG. 111B

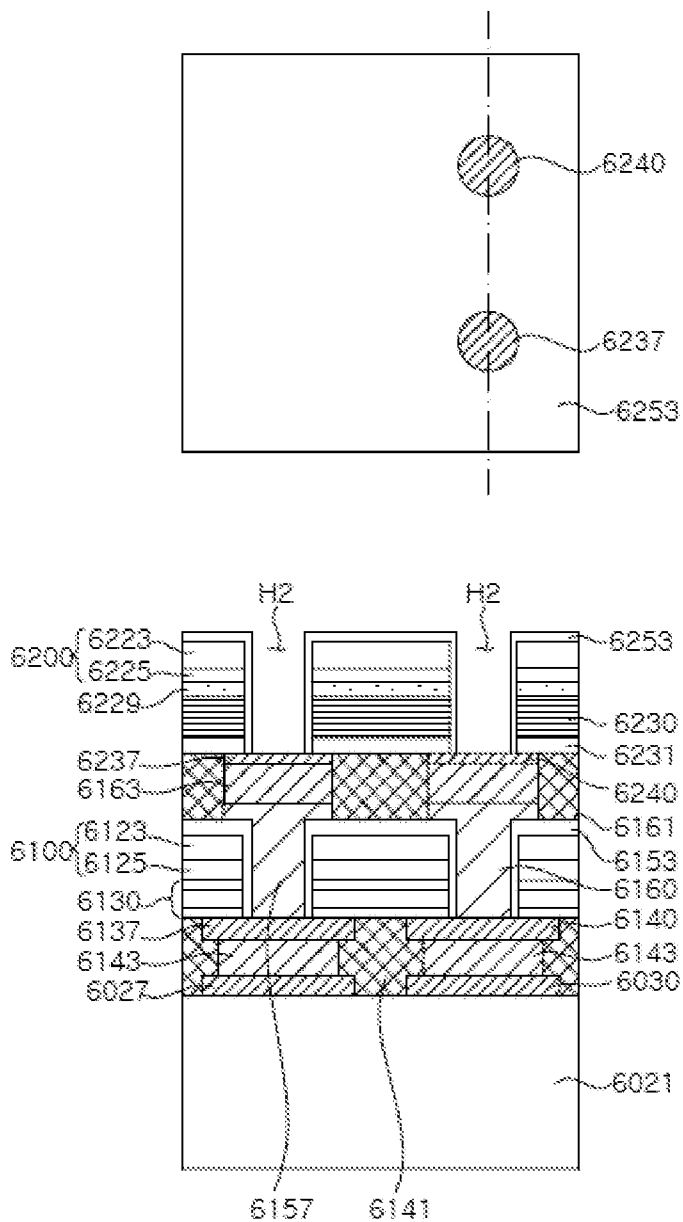


FIG. 111C

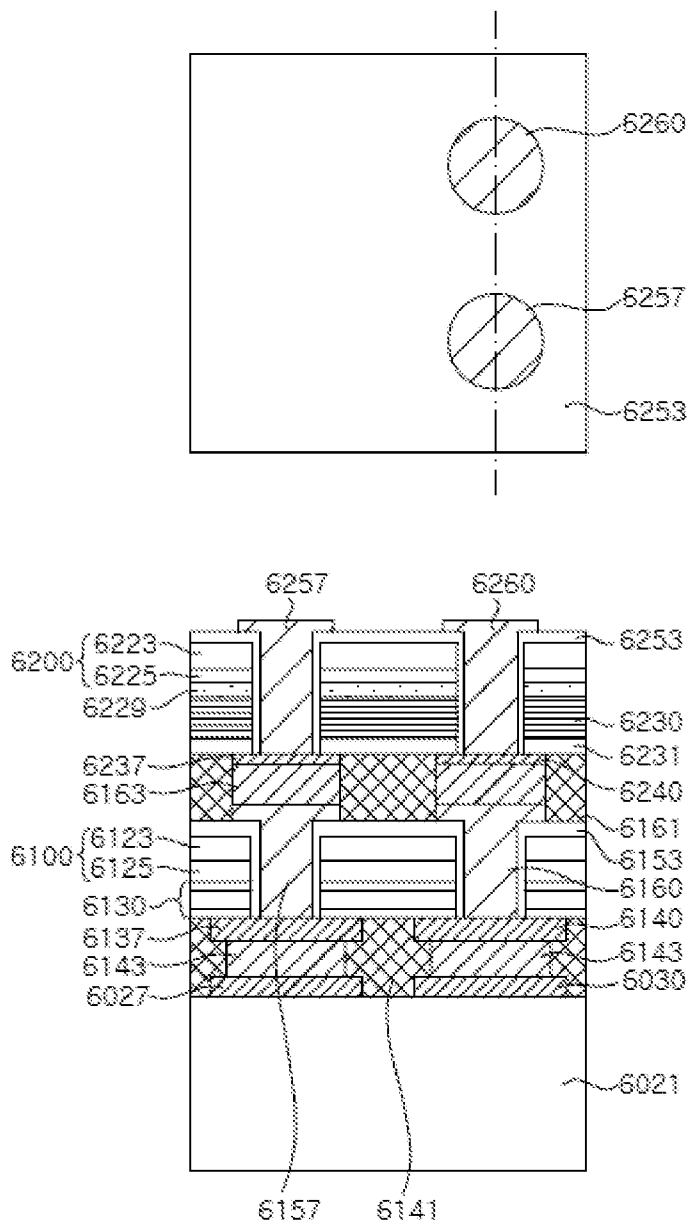


FIG. 111D

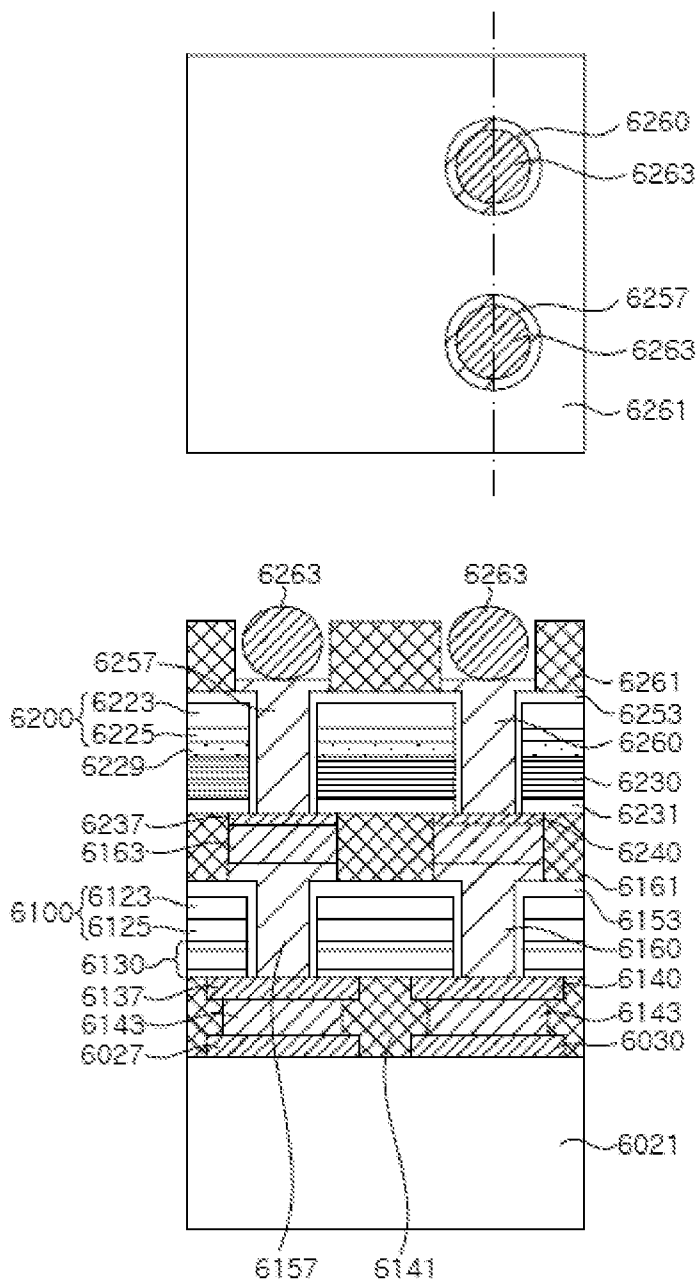


FIG. 112A

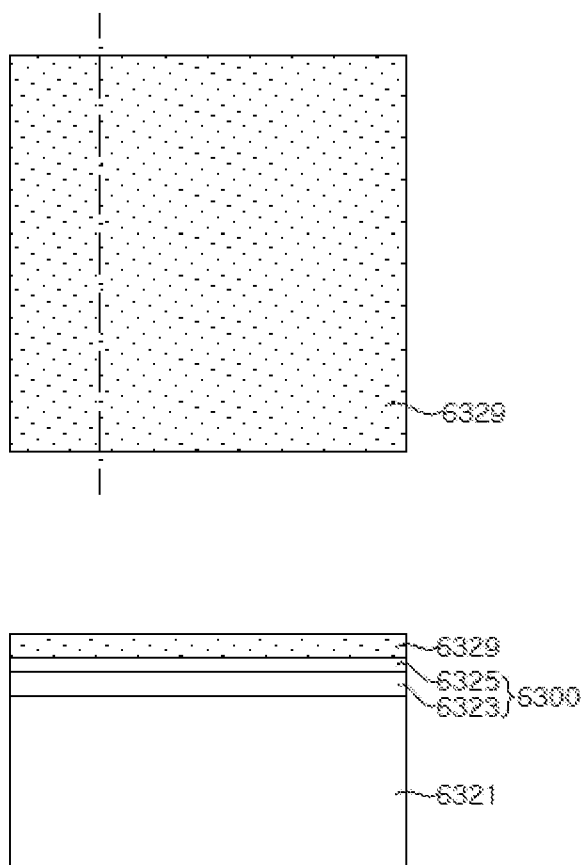


FIG. 112B

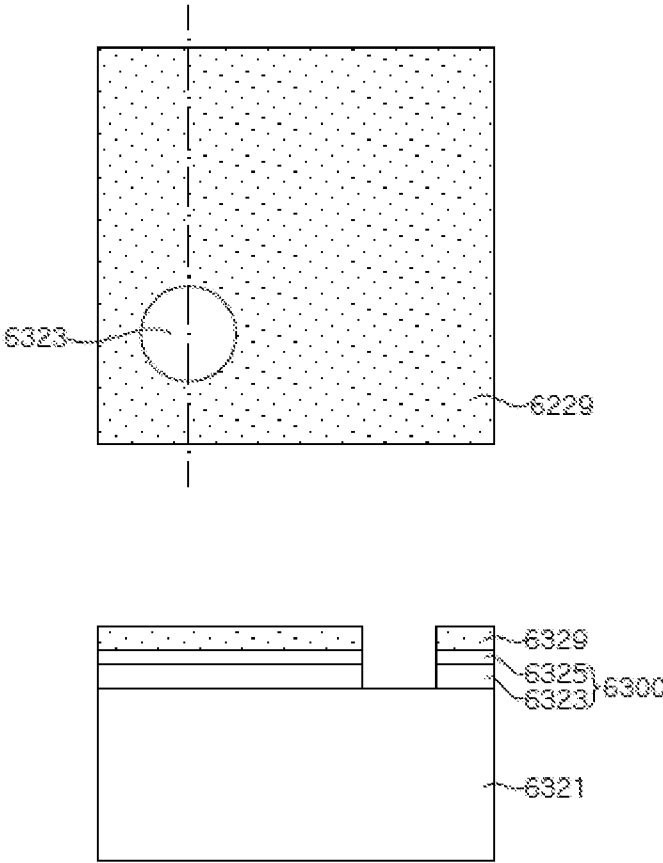


FIG. 112C

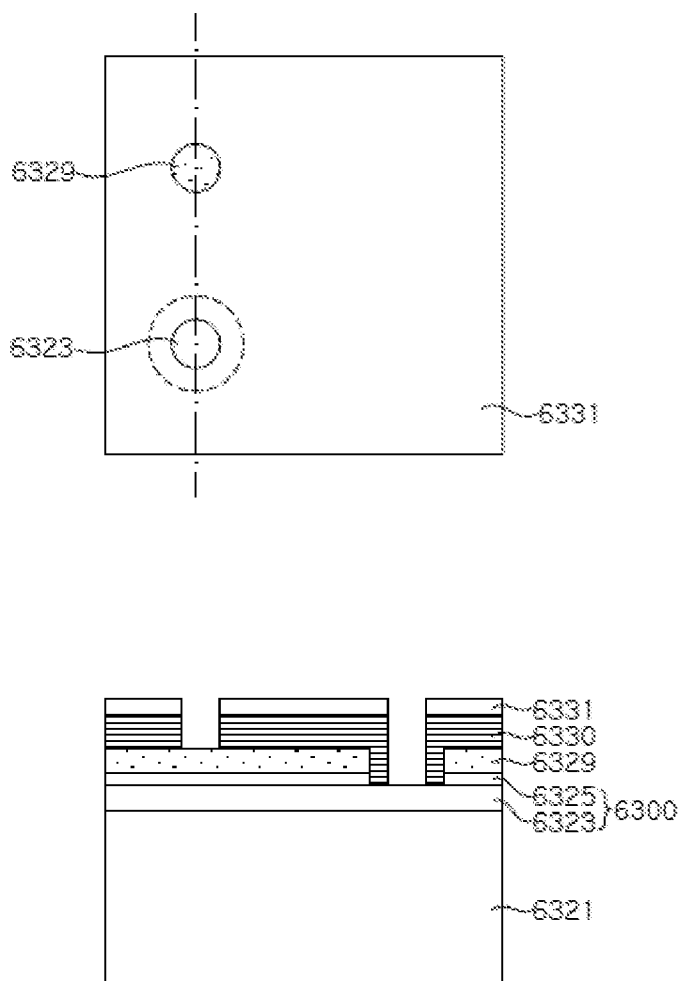


FIG. 112D

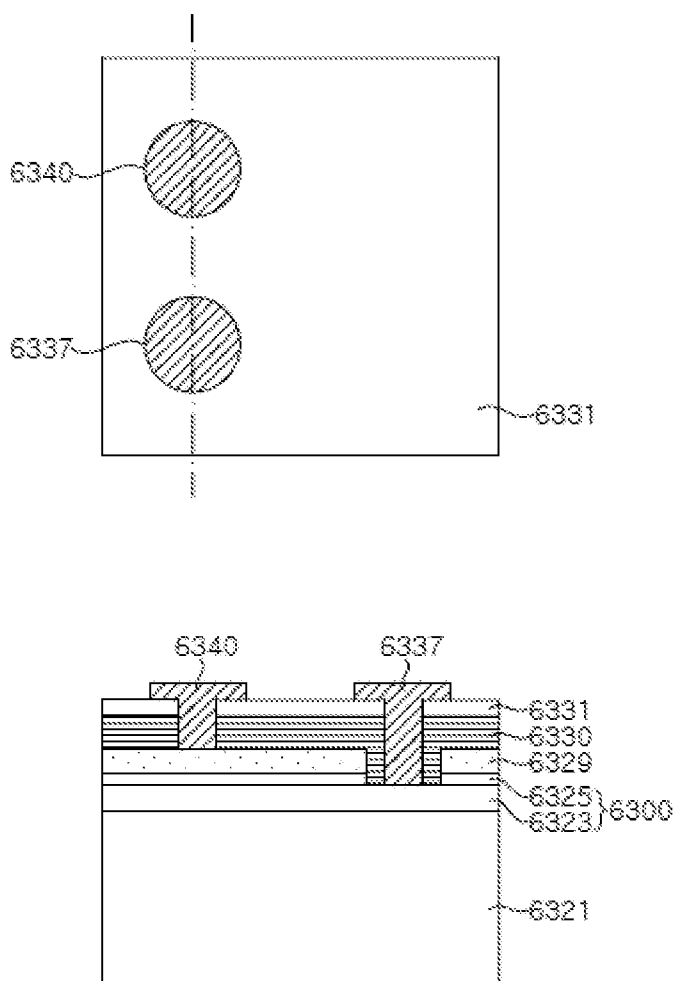


FIG. 113A

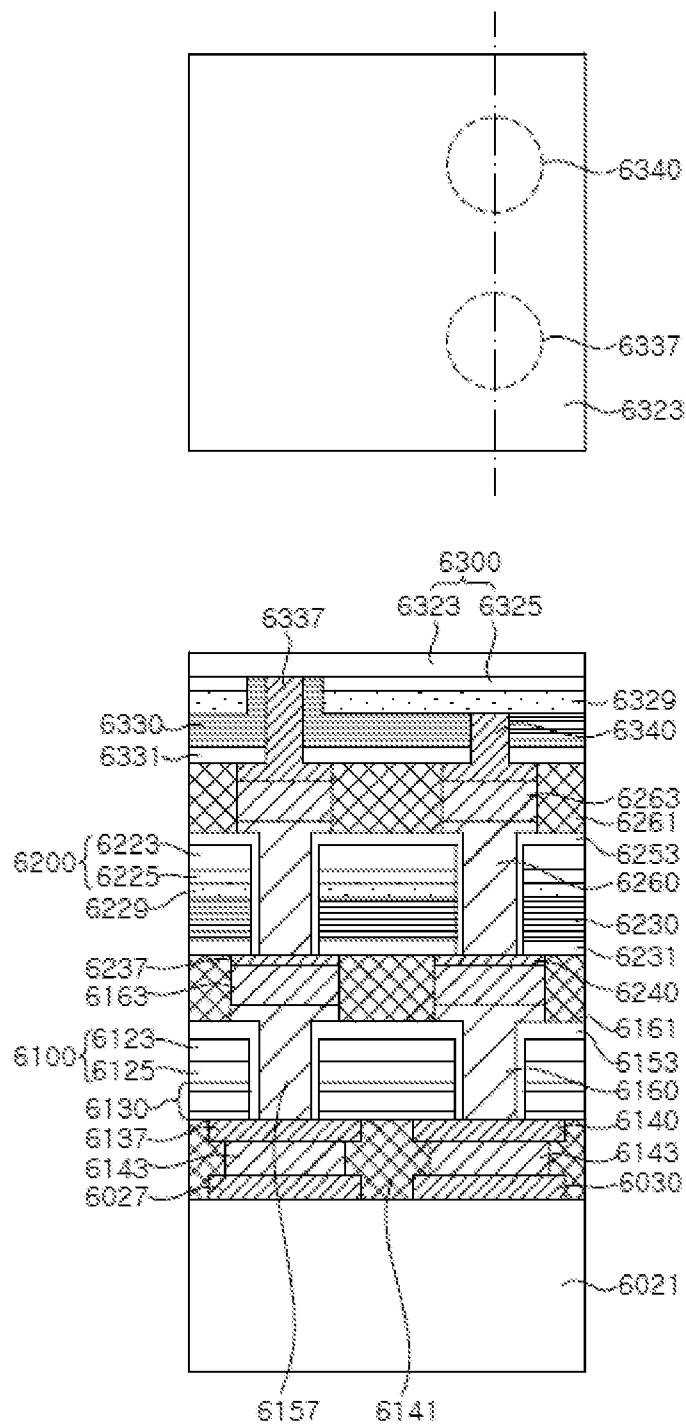


FIG. 113B

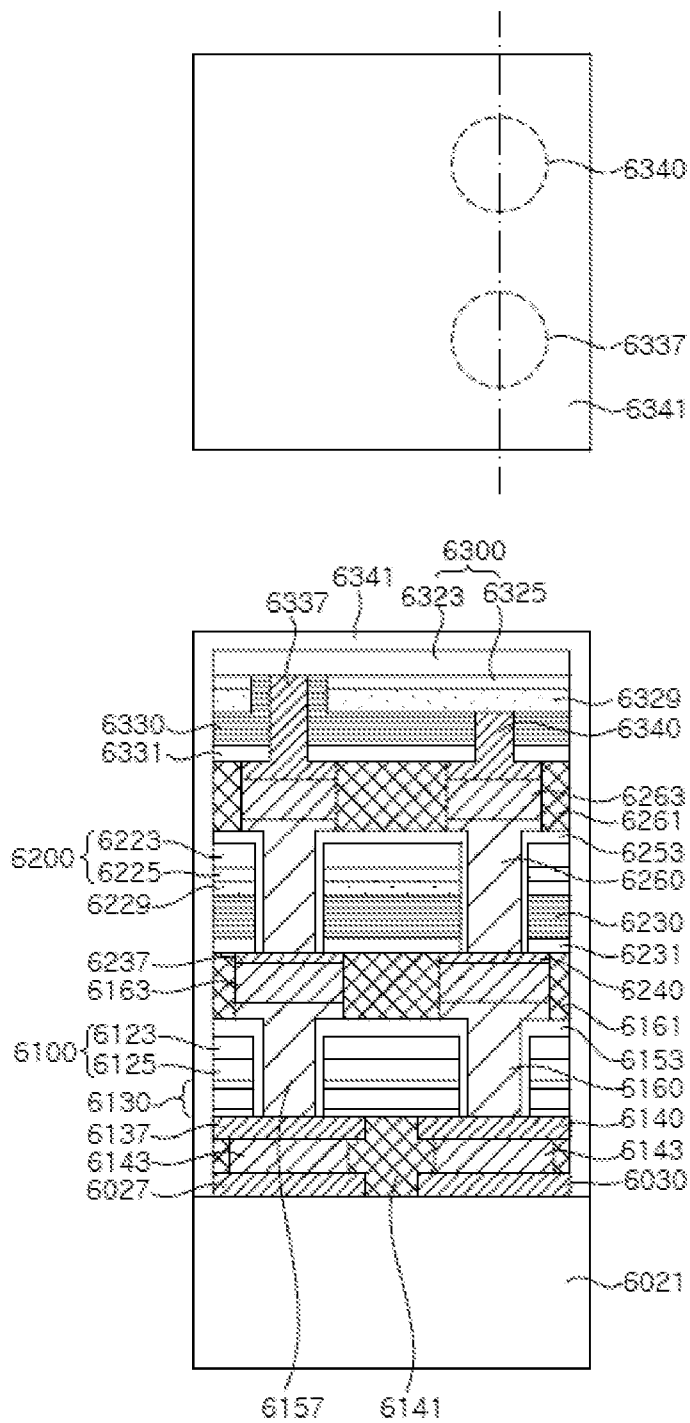


FIG. 114

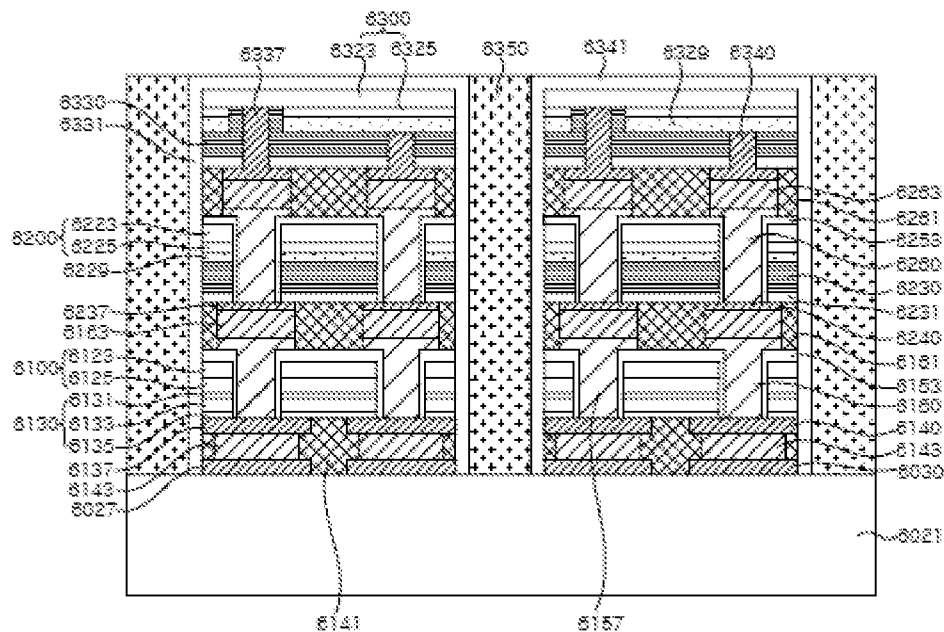


FIG. 115A

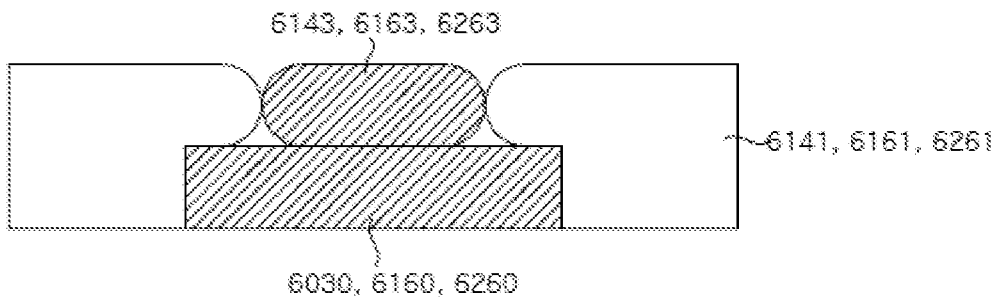


FIG. 115B

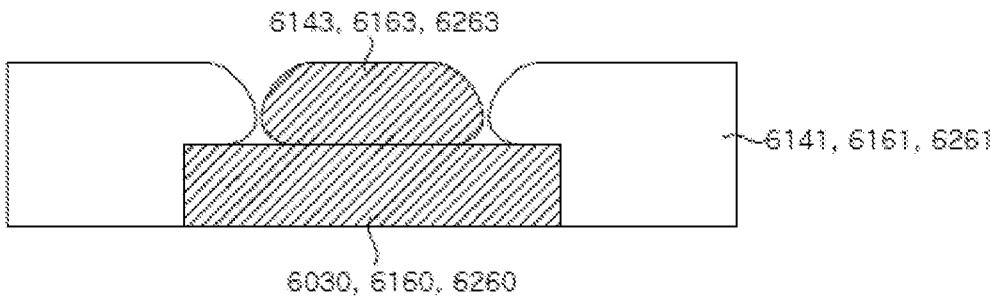
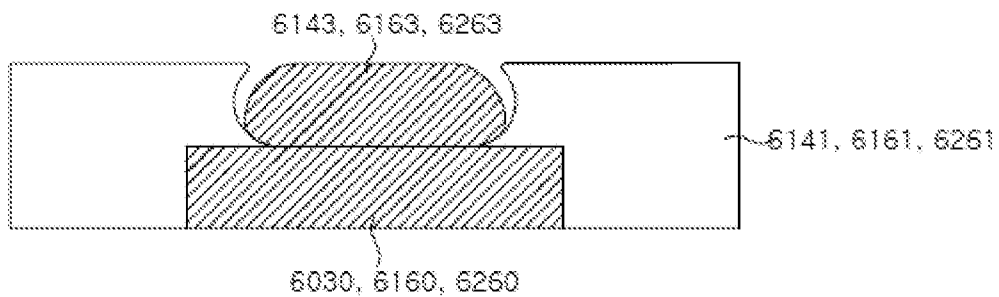


FIG. 115C



LED UNIT FOR DISPLAY AND DISPLAY APPARATUS HAVING THE SAME

CROSS REFERENCES TO RELATED APPLICATIONS

[0001] This application claims priority from and the benefit of United States Provisional Patent Application No. 62/590,870, filed on Nov. 27, 2017, U.S. Provisional Patent Application No. 62/590,854, filed on Nov. 27, 2017, U.S. Provisional Patent Application No. 62/594,769, filed on Dec. 5, 2017, U.S. Provisional Patent Application No. 62/595,932, filed on Dec. 7, 2017, U.S. Provisional Patent Application No. 62/608,297, filed on Dec. 20, 2017, United States Provisional Patent Application No. 62/614,900, filed on Jan. 8, 2018, U.S. Provisional Patent Application No. 62/635,284, filed on Feb. 26, 2018, and U.S. Provisional Patent Application No. 62/683,564, filed on Jun. 11, 2018, the disclosures of which are hereby incorporated by reference for all purposes as if fully set forth herein.

BACKGROUND

Field

[0002] Exemplary implementations of the invention relate generally to a display apparatus and, more particularly, to a display apparatus having a light emitting diode (LED) unit pixel, a light emitting device for a display and a display apparatus, and to a light emitting device for a display with stacked structure of a plurality of LEDs and a display apparatus having the same.

Discussion of the Background

[0003] A light emitting diode has been used as an inorganic light source in various fields such as display apparatuses, automotive lamps, and general lighting. With advantages of long lifespan, low power consumption, and high response speed, the light emitting diode has been rapidly replacing a conventional light source.

[0004] Meanwhile, a light emitting diode of the related art has been mainly used as a backlight light source in a display apparatus. However, a micro LED display has been recently developed as a next-generation display that directly implements an image using the light emitting diode.

[0005] In general, the display apparatus implements various colors by using mixed colors of blue, green, and red. The display apparatus includes a plurality of pixels to implement an image with various colors, and each of pixels includes sub-pixels of blue, green, and red. The color of a specific pixel is determined by the color of the sub-pixels, and the image is implemented by the combination of these pixels.

[0006] In the case of a micro LED display, the micro LEDs corresponding to each sub-pixel are arranged on a two-dimensional plane. Therefore, a large number of micro LEDs are required to be disposed on one substrate. However, the micro LED has a very small size having a surface area of 10,000 square m or less, and thus, there are various problems due to this small size. Particularly, it is difficult to handle a light emitting diode having a small size, and it is not easy to mount the light emitting diode on a display panel, especially over hundreds of thousands or millions, and to replace a defective LED of mounted micro LEDs with a good LED.

[0007] In addition, since sub-pixels are arranged on a two-dimensional plane, the area occupied by one pixel including the sub-pixels of blue, green, and red is relatively increased. Therefore, in order to arrange the sub-pixels within a limited area, it is required to reduce the area of each sub-pixel, thereby causing deterioration in brightness through reduction in luminous area.

[0008] The above information disclosed in this Background section is only for understanding of the background of the inventive concepts, and, therefore, it may contain information that does not constitute prior art.

SUMMARY

[0009] Light emitting diodes constructed according to the principles and some exemplary implementations of the invention and displays using the same are capable of increasing a light emitting area of each sub-pixel without increasing the pixel area.

[0010] Light emitting diodes and display using the light emitting diodes, e.g., micro LEDs, constructed according to the principles and some exemplary implementations of the invention provide high reliability due to a stable LED structure and simplified manufacturing process in which a single via may be connected to one or more of semiconductor layers of each of the LED stacks.

[0011] Light emitting diodes and display using the light emitting diodes, e.g., micro LEDs, constructed according to the principles and some exemplary implementations of the invention provide pixels that can be simultaneously manufactured to obviate the cumbersome process of individually mounting the pixels.

[0012] Light emitting diodes and display using the light emitting diodes, e.g., micro LEDs, constructed according to the principles and some exemplary implementations of the invention are capable of being driven in an active matrix manner.

[0013] Light emitting diodes and display using the light emitting diodes, e.g., micro LEDs, constructed according to the principles and some exemplary implementations of the invention are capable of shortening a mounting process time.

[0014] Light emitting diodes and display using the light emitting diodes, e.g., micro LEDs, constructed according to the principles and some exemplary implementations of the invention are capable of preventing light interference between LED stacks by arranging first, second, and third LED stacks one over another to emit light with decreasing wavelengths of light. For example, the first, second, and third LED stacks may emit red light, green light, and blue light, respectively.

[0015] Light emitting diodes and display using the light emitting diodes, e.g., micro LEDs, constructed according to the principles and some exemplary implementations of the invention are capable of suppressing generation of secondary light between the LED stacks without arrangement of the color filters therebetween, which are generally formed between the LED stacks to prevent generation of secondary light by light emitted from adjacent LED stacks.

[0016] Additional features of the inventive concepts will be set forth in the description which follows, and in part will be apparent from the description, or may be learned by practice of the inventive concepts.

[0017] A display apparatus according to an exemplary embodiment includes a thin film transistor (TFT) substrate,

a first LED sub-unit disposed on the TFT substrate, a second LED sub-unit disposed on the first LED sub-unit, a third LED sub-unit disposed on the second LED sub-unit, electrode pads disposed between the TFT substrate and the first LED sub-unit, and connectors connecting the first, second, and third LED sub-units to a respective one of the electrode pads, in which the first LED sub-unit, the second LED sub-unit, and the third LED sub-unit are configured to be independently driven, light generated from the first LED sub-unit is configured to be emitted to the outside of the display apparatus by passing through the second LED sub-unit and the third LED sub-unit, and light generated from the second LED sub-unit is configured to be emitted to the outside of the display apparatus by passing through the third LED sub-unit.

[0018] The first, second, and third LED sub-units may include a first LED stack, a second LED stack, and a third LED stack, respectively, and the first, second, and third LED stacks may be configured to emit red light, green light, and blue light, respectively.

[0019] The display apparatus may include a first reflective electrode disposed between the TFT substrate and the first LED sub-unit and in contact with a lower surface of the first LED sub-unit, in which the connectors may include a first lower connector connecting the first reflective electrode to a first one of the electrode pads.

[0020] The connectors may further include a first upper connector connecting an upper surface of the first LED sub-unit to a second one of the electrode pads.

[0021] The display apparatus may further include a second transparent electrode interposed between the first LED sub-unit and the second LED sub-unit and in ohmic contact with a lower surface of the second LED sub-unit, and a third transparent electrode interposed between the second LED sub-unit and the third LED sub-unit and in ohmic contact with a lower surface of the third LED sub-unit, in which the connectors may further include a second lower connector connecting the second transparent electrode to the first one of the electrode pads, a second upper connector connecting an upper surface of the second LED sub-unit to a third one of the electrode pads, a third lower connector connecting the third transparent electrode to the first one of the electrode pads, and a third upper connector connecting an upper surface of the third LED sub-unit to a fourth one of the electrode pads.

[0022] The first lower connector may be connected to an upper surface of the first reflective electrode, the second lower connector may be connected to an upper surface of the second transparent electrode, and the third lower connector may be connected to an upper surface of the third transparent electrode.

[0023] The first upper connector may be connected to the upper surface of the first LED sub-unit, the second upper connector may be connected to the upper surface of the second LED sub-unit, the third upper connector may be connected to the upper surface of the third LED sub-unit, and at least one of the upper connectors may be substantially annular in shape.

[0024] The connectors may further include intermediate connectors connecting the second upper connector and the third upper connector to the third one and the fourth one of the electrode pads, respectively.

[0025] Each of the connectors may pass through at least one of the first, second, and third LED sub-units.

[0026] The first lower connector, the second lower connector, and the third lower connector may be connected to the first one of the electrode pads, and the first upper connector, the second upper connector, and the third upper connector may be connected to different ones of the electrode pads, respectively.

[0027] The first lower connector, the second lower connector, and the third lower connector may be stacked over each other in a vertical direction, and the first upper connector, the second upper connector, and the third upper connector may be spaced apart from each other in the vertical direction and in a lateral direction.

[0028] The display apparatus may further include a second transparent electrode interposed between the first LED sub-unit and the second LED sub-unit and in ohmic contact with a lower surface of the second LED sub-unit, and a third transparent electrode interposed between the second LED sub-unit and the third LED sub-unit and in ohmic contact with a lower surface of the third LED sub-unit, in which the connectors may further include a second lower connector connecting the second transparent electrode to a third one of the electrode pads, a second upper connector connecting an upper surface of the second LED sub-unit to the second one of the electrode pads, a third lower connector connecting the third transparent electrode to a fourth one of the electrode pads, and a third upper connector connecting an upper surface of the third LED sub-unit to the second one of the electrode pads, and the first lower connector, the second lower connector, and the third lower connector may be separated from each other and are connected to the first, third, and fourth ones of the electrode pads, respectively, and the first upper connector, the second upper connector, and the third upper connector may be electrically connected to the second one of the electrode pads.

[0029] The first lower connector, the second lower connector, and the third lower connector may be spaced apart from each other in a vertical direction and in a lateral direction, and the first upper connector, the second upper connector, and the third upper connector may be stacked in the vertical direction.

[0030] The display apparatus may further include a first color filter interposed between the first LED sub-unit and the second LED sub-unit, and configured to transmit light generated from the first LED sub-unit and reflect light generated from the second LED sub-unit, and a second color filter interposed between the second LED sub-unit and the third LED sub-unit, and configured to transmit light generated from the first and second LED sub-units and reflect light generated from the third LED sub-unit.

[0031] The display apparatus may further include a first bonding layer interposed between the TFT substrate and the first LED sub-unit, a second bonding layer interposed between the first LED sub-unit and the second LED sub-unit, and a third bonding layer interposed between the second LED sub-unit and the third LED sub-unit, in which the second bonding layer is configured to transmit light generated from the first LED sub-unit, and the third bonding layer is configured to transmit light generated from the first and second LED sub-units.

[0032] The display apparatus may be configured to be driven in an active matrix manner.

[0033] The third lower connector and the third upper connector may be exposed by the third LED sub-unit in plan view.

[0034] The first reflective electrode may be disposed between the first LED sub-unit and the electrode pads.

[0035] The first, second and third LED subunits may include a micro LED having a surface area less than about 10,000 square m.

[0036] The first LED sub-unit may be configured to emit one of red, green, and blue light, the second LED sub-unit may be configured to emit a different one of red, green, and blue light from the first LED sub-unit, and the third LED sub-unit may be configured to emit a different one of red, green, and blue light from the first and second LED sub-units.

[0037] A light emitting device according to an exemplary embodiment includes a first LED sub-unit, a second LED sub-unit disposed adjacent to the first LED sub-unit, a third LED sub-unit disposed adjacent to the second LED sub-unit, and electrode pads disposed on the first LED sub-unit and electrically connected to the first, second, and third LED sub-units, the electrode pads including a common electrode pad electrically connected to each of the first, second, and third LED sub-units, and first, second, and third electrode pads connected to a respective one of the first, second, and third LED sub-units, in which the common electrode pad, the second electrode pad, and the third electrode pad are electrically connected to the second LED sub-unit and the third LED sub-unit through holes that pass through the first LED sub-unit, the first LED sub-unit, the second LED sub-unit, and the third LED sub-unit are configured to be independently driven, light generated in the first LED sub-unit is configured to be emitted to the outside of the light emitting device through the second LED sub-unit and the third LED sub-unit, and light generated in the second LED sub-unit is configured to be emitted to the outside of the light emitting device through the third LED sub-unit.

[0038] The first, second, and third LED sub-units may include a first LED stack, a second, LED stack, and a third LED stack, respectively, and the first, second, and third LED stacks may be configured to emit red light, green light, and blue light, respectively.

[0039] The light emitting device may further include a first reflective electrode disposed between the electrode pads and the first LED sub-unit and in ohmic contact with the first LED sub-unit, in which the common electrode pad is connected to the first reflective electrode.

[0040] The first reflective electrode may include an ohmic contact layer in ohmic contact with an upper surface of the first LED sub-unit and a reflective layer that covers the ohmic contact layer.

[0041] The first reflective electrode may have a hollow portion defined by a substantially annular-shaped member, and the common electrode pad may pass through the hollow portion of the substantially annular-shaped member.

[0042] The light emitting device may further include a second transparent electrode interposed between the second LED sub-unit and the third LED sub-unit and in ohmic contact with a lower surface of the second LED sub-unit, and a third transparent electrode in ohmic contact with an upper surface of the third LED sub-unit, in which the common electrode pad may be electrically connected to the second transparent electrode and the third transparent electrode.

[0043] The common electrode pad may be connected to an upper surface of the second transparent electrode and an upper surface of the third transparent electrode.

[0044] Each of the first LED sub-unit and the third LED sub-unit may include a first conductivity type semiconductor layer and a second conductivity type semiconductor layer disposed on a partial region of the first conductivity type semiconductor layer, and the first electrode pad and the third electrode pad may be electrically connected to the first conductivity type semiconductor layer of the first LED sub-unit and the third LED sub-unit, respectively.

[0045] The light emitting device may further include a first ohmic electrode disposed on the first conductivity type semiconductor layer of the first LED sub-unit, in which the first electrode pad is connected to the first ohmic electrode.

[0046] The third electrode pad may be directly connected to the first conductivity type semiconductor layer of the third LED sub-unit.

[0047] The light emitting device may further include a first color filter disposed between the third transparent electrode and the second LED sub-unit, and a second color filter disposed between the first and second LED sub-units.

[0048] The first color filter and the second color filter may include insulating layers having different refractive indices.

[0049] The common electrode pad and the third electrode pad may be electrically connected to the third LED sub-unit through holes that pass through the second LED sub-unit.

[0050] The light emitting device may further include a substrate on which the third LED sub-unit is disposed.

[0051] The substrate may include a sapphire substrate or a gallium nitride substrate.

[0052] The light emitting device may further include an insulating layer disposed between the first LED sub-unit and the electrode pads, in which the electrode pads are electrically connected to the first, second, and third LED sub-units through the insulating layer.

[0053] The insulating layer may include at least one of a distributed Bragg reflector and a light blocking material.

[0054] A display apparatus may include a circuit board, and a plurality of light emitting devices arranged on the circuit board, at least some of the light emitting devices may include the light emitting device according to an exemplary embodiment, in which the electrode pads may be electrically connected to the circuit board.

[0055] Each of the light emitting devices may include a substrate coupled to the third LED sub-unit, and the substrates of the light emitting devices may be spaced apart from each other.

[0056] A light emitting device according to an exemplary embodiment includes a substrate, a first LED sub-unit disposed on the substrate, a second LED sub-unit disposed on the first LED sub-unit, a third LED sub-unit disposed on the second LED sub-unit, and electrode pads electrically connected to the first, second, and third LED sub-units, the electrode pads including a common electrode pad electrically connected to each of the first, second, and third LED sub-units by a single through-hole via, and first, second, and third electrode pads connected to a respective one of the first, second, and third LED sub-units.

[0057] The electrode pads may be disposed between the substrate and the first LED sub-unit, the through-hole via may include a plurality of connectors connected to each of the first, second, and third LED sub-units, and the connectors may include a first portion having a width greater than a width of the through-hole via.

[0058] The first LED sub-unit may include a reflective electrode disposed on a lower surface thereof, and the reflective electrode may contact the first portion of the corresponding connector.

[0059] The first, second, and third LED sub-units may be disposed between the electrode pads and the substrate, and the through-hole via may have a width that narrows in a direction from the electrode pads to the substrate.

[0060] The third LED sub-unit may include a reflective electrode disposed on an upper surface thereof, and the common electrode pad may directly contact the reflective electrode.

[0061] It is to be understood that both the foregoing general description and the following detailed description are exemplary and explanatory and are intended to provide further explanation of the invention as claimed.

BRIEF DESCRIPTION OF THE DRAWINGS

[0062] The accompanying drawings, which are included to provide a further understanding of the invention and are incorporated in and constitute a part of this specification, illustrate exemplary embodiments of the invention, and together with the description serve to explain the inventive concepts.

[0063] FIG. 1 is a schematic plan view of a display apparatus according to an exemplary embodiment.

[0064] FIG. 2 is a schematic cross-sectional view taken along line A-A of FIG. 1.

[0065] FIGS. 3A, 3B, 4A, 4B, 5A, 5B, 6A, 6B, 7A, 7B, 8A, 8B, 9A, 9B, 10A, 10B, 11A, 11B, 12A, 12B, 13A, 13B, 14A, 14B, 15A, 15B, 16A, and 16B are schematic plan views and schematic cross-sectional views illustrating a method of manufacturing a display apparatus according to an exemplary embodiment.

[0066] FIG. 17 is a schematic plan view of a display apparatus according to another exemplary embodiment.

[0067] FIG. 18 is a schematic cross-sectional view taken along line B-B of FIG. 17.

[0068] FIG. 19 is a schematic circuit diagram of a display apparatus according to an exemplary embodiment.

[0069] FIG. 20 is a schematic plan view of a display apparatus according to an exemplary embodiment.

[0070] FIG. 21A is a schematic plan view of a light emitting device according to an exemplary embodiment.

[0071] FIG. 21B is a schematic cross-sectional view taken along line A-A of FIG. 21A.

[0072] FIGS. 22, 23, 24, 25, 26A, 26B, 27A, 27B, 28A, 28B, 29, 30A, 30B, 31A, 31B, 32A, 32B, 33A, 33B, 34A, 34B, 35A, and 35B are schematic plan views and cross-sectional views illustrating a method of manufacturing a light emitting device according to an exemplary embodiment.

[0073] FIG. 36 is a schematic cross-sectional view of a light emitting diode stack for a display according to an exemplary embodiment.

[0074] FIGS. 37A, 37B, 37C, 37D, and 37E are schematic cross-sectional views illustrating a method of manufacturing a light emitting diode stack for a display according to an exemplary embodiment.

[0075] FIG. 38 is a schematic circuit diagram of a display apparatus according to an exemplary embodiment.

[0076] FIG. 39 is a schematic plan view of a display apparatus according to an exemplary embodiment.

[0077] FIG. 40 is an enlarged plan view of one pixel of the display apparatus of FIG. 39.

[0078] FIG. 41 is a schematic cross-sectional view taken along line A-A of FIG. 40.

[0079] FIG. 42 is a schematic cross-sectional view taken along line B-B of FIG. 40.

[0080] FIGS. 43A, 43B, 43C, 43D, 43E, 43F, 43G, 43H, 43I, 43J, and 43K are schematic cross-sectional views illustrating a method of manufacturing a display apparatus according to an exemplary embodiment.

[0081] FIG. 44 is a schematic circuit diagram of a display apparatus according to another exemplary embodiment.

[0082] FIG. 45 is a schematic plan view of a display apparatus according to another exemplary embodiment.

[0083] FIG. 46 is a schematic cross-sectional view of a light emitting diode stack for a display according to an exemplary embodiment.

[0084] FIGS. 47A, 47B, 47C, 47D, and 47E are schematic cross-sectional views illustrating a method of manufacturing a light emitting diode stack for a display according to an exemplary embodiment.

[0085] FIG. 48 is a schematic circuit diagram of a display apparatus according to an exemplary embodiment.

[0086] FIG. 49 is a schematic plan view of the display apparatus according to an exemplary embodiment.

[0087] FIG. 50 is an enlarged plan view of one pixel of the display apparatus of FIG. 49.

[0088] FIG. 51 is a schematic cross-sectional view taken along line A-A of FIG. 50.

[0089] FIG. 52 is a schematic cross-sectional view taken along line B-B of FIG. 50.

[0090] FIGS. 53A, 53B, 53C, 53D, 53E, 53F, 53G, 53H, 53I, 53J, and 53K are schematic cross-sectional views illustrating a method of manufacturing a display apparatus according to an exemplary embodiment.

[0091] FIG. 54 is a schematic circuit diagram of a display apparatus according to another exemplary embodiment.

[0092] FIG. 55 is a schematic plan view of a display apparatus according to another exemplary embodiment.

[0093] FIG. 56 is a schematic plan view of a display apparatus according to an exemplary embodiment.

[0094] FIG. 57 is a schematic cross-sectional view of a light emitting diode pixel for a display according to an exemplary embodiment.

[0095] FIG. 58 is a schematic circuit diagram of a display apparatus according to an exemplary embodiment.

[0096] FIG. 59A and FIG. 59B are a top view and a bottom view of one pixel of a display apparatus according to an exemplary embodiment.

[0097] FIG. 60A is a schematic cross-sectional view taken along line A-A of FIG. 59A.

[0098] FIG. 60B is a schematic cross-sectional view taken along line B-B of FIG. 59A.

[0099] FIG. 60C is a schematic cross-sectional view taken along line C-C of FIG. 59A.

[0100] FIG. 60D is a schematic cross-sectional view taken along line D-D of FIG. 59A.

[0101] FIGS. 61A, 61B, 62A, 62B, 63A, 63B, 64A, 64B, 65A, 65B, 66A, 66B, 67A, 67B, 68A, and 68B are schematic plan views and schematic cross-sectional view illustrating a method of manufacturing a display apparatus according to an exemplary embodiment.

[0102] FIG. 69 is a schematic cross-sectional view of a light emitting diode pixel for a display according to another exemplary embodiment.

[0103] FIG. 70 is an enlarged top view of one pixel of a display apparatus according to an exemplary embodiment.

[0104] FIG. 71A and FIG. 71B are cross-sectional views taken along lines G-G and H-H in FIG. 70, respectively.

[0105] FIG. 72 is a schematic cross-sectional view of a light emitting diode (LED) stack for a display according to an exemplary embodiment.

[0106] FIGS. 73A, 73B, 73C, 73D, 73E, and 73F are schematic cross-sectional views illustrating a method for manufacturing a light emitting diode stack for a display according to an exemplary embodiment.

[0107] FIG. 74 is a schematic circuit diagram of a display apparatus according to an exemplary embodiment.

[0108] FIG. 75 is a schematic plan view of a display apparatus according to an exemplary embodiment.

[0109] FIG. 76 is an enlarged plan view of one pixel of the display apparatus of FIG. 75.

[0110] FIG. 77 is a schematic cross-sectional view taken along line A-A of FIG. 76.

[0111] FIG. 78 is a schematic cross-sectional view taken along line B-B of FIG. 76.

[0112] FIGS. 79A, 79B, 79C, 79D, 79E, 79F, 79G, and 79H are schematic plan views illustrating a method for manufacturing a display apparatus according to an exemplary embodiment.

[0113] FIG. 80 is a schematic cross-sectional view of a light emitting stacked structure according to an exemplary embodiment.

[0114] FIGS. 81A and 81B are cross-sectional views of a light emitting stacked structure according to exemplary embodiments.

[0115] FIG. 82 is a cross-sectional view of a light emitting stacked structure including a wiring part according to an exemplary embodiment.

[0116] FIG. 83 is a cross-section view of a light emitting stacked structure according to an exemplary embodiment.

[0117] FIG. 84 is a plan view of a display device according to an exemplary embodiment.

[0118] FIG. 85 is an enlarged plan view of portion P1 of FIG. 84.

[0119] FIG. 86 is a structural diagram of a display device according to an exemplary embodiment.

[0120] FIG. 87 is a circuit diagram of one pixel of a passive type display device.

[0121] FIG. 88 is a circuit diagram of one pixel of an active type display device.

[0122] FIG. 89 is a plan view of a pixel according to an exemplary embodiment.

[0123] FIGS. 90A and 90B are cross-sectional views taken along lines I-I' and II-II' of FIG. 89, respectively.

[0124] FIGS. 91A, 91B, and 91C are cross-sectional views taken along line I-I' in FIG. 89, illustrating a process of stacking first to third epitaxial stacks on a substrate according to an exemplary embodiment.

[0125] FIGS. 92, 94, 96, 98, 100, 102, 104 are plan views sequentially illustrating a method of manufacturing a pixel on a substrate.

[0126] FIGS. 93A, 95A, 97A, 99A, 101A, 103A, and 105A are cross-sectional views taken along line I-I' of FIGS. 92, 94, 96, 98, 100, 102, 104, respectively.

[0127] FIGS. 93B, 95B, 97B, 99B, 101B, 103B, and 105B are cross-sectional views taken along line II-II' of FIGS. 92, 94, 96, 98, 100, 102, 104, respectively.

[0128] FIG. 106 is a schematic plan view of a display apparatus according to an exemplary embodiment.

[0129] FIG. 107A is a cross-sectional view of the display apparatus of FIG. 106.

[0130] FIG. 107B is a schematic circuit diagram of a display apparatus according to an exemplary embodiment.

[0131] FIGS. 108A, 108B, 108C, 108D, 108E, 109A, 109B, 109C, 109D, 109E, 110A, 110B, 110C, 110D, 111A, 111B, 111C, 111D, 112A, 112B, 112C, 112D, 113A, 113B, and 114 are schematic plan views and cross-sectional views illustrating a manufacturing method of a display apparatus according to an exemplary embodiment.

[0132] FIGS. 115A, 115B, and 115C are schematic cross-sectional views of a metal bonding material according to exemplary embodiments.

DETAILED DESCRIPTION

[0133] In the following description, for the purposes of explanation, numerous specific details are set forth in order to provide a thorough understanding of various exemplary embodiments or implementations of the invention. As used herein “embodiments” and “implementations” are interchangeable words that are non-limiting examples of devices or methods employing one or more of the inventive concepts disclosed herein. It is apparent, however, that various exemplary embodiments may be practiced without these specific details or with one or more equivalent arrangements. In other instances, well-known structures and devices are shown in block diagram form in order to avoid unnecessarily obscuring various exemplary embodiments. Further, various exemplary embodiments may be different, but do not have to be exclusive. For example, specific shapes, configurations, and characteristics of an exemplary embodiment may be used or implemented in another exemplary embodiment without departing from the inventive concepts.

[0134] Unless otherwise specified, the illustrated exemplary embodiments are to be understood as providing exemplary features of varying detail of some ways in which the inventive concepts may be implemented in practice. Therefore, unless otherwise specified, the features, components, modules, layers, films, panels, regions, and/or aspects, etc. (hereinafter individually or collectively referred to as “elements”), of the various embodiments may be otherwise combined, separated, interchanged, and/or rearranged without departing from the inventive concepts.

[0135] The use of cross-hatching and/or shading in the accompanying drawings is generally provided to clarify boundaries between adjacent elements. As such, neither the presence nor the absence of cross-hatching or shading conveys or indicates any preference or requirement for particular materials, material properties, dimensions, proportions, commonalities between illustrated elements, and/or any other characteristic, attribute, property, etc., of the elements, unless specified. Further, in the accompanying drawings, the size and relative sizes of elements may be exaggerated for clarity and/or descriptive purposes. When an exemplary embodiment may be implemented differently, a specific process order may be performed differently from the described order. For example, two consecutively described processes may be performed substantially at the

same time or performed in an order opposite to the described order. Also, like reference numerals denote like elements.

[0136] When an element, such as a layer, is referred to as being “on,” “connected to,” or “coupled to” another element or layer, it may be directly on, connected to, or coupled to the other element or layer or intervening elements or layers may be present. When, however, an element or layer is referred to as being “directly on,” “directly connected to,” or “directly coupled to” another element or layer, there are no intervening elements or layers present. To this end, the term “connected” may refer to physical, electrical, and/or fluid connection, with or without intervening elements. Further, the D1-axis, the D2-axis, and the D3-axis are not limited to three axes of a rectangular coordinate system, such as the x, y, and z-axes, and may be interpreted in a broader sense. For example, the D1-axis, the D2-axis, and the D3-axis may be perpendicular to one another, or may represent different directions that are not perpendicular to one another. For the purposes of this disclosure, “at least one of X, Y, and Z” and “at least one selected from the group consisting of X, Y, and Z” may be construed as X only, Y only, Z only, or any combination of two or more of X, Y, and Z, such as, for instance, XYZ, XYY, YZ, and ZZ. As used herein, the term “and/or” includes any and all combinations of one or more of the associated listed items.

[0137] Although the terms “first,” “second,” etc. may be used herein to describe various types of elements, these elements should not be limited by these terms. These terms are used to distinguish one element from another element. Thus, a first element discussed below could be termed a second element without departing from the teachings of the disclosure.

[0138] Spatially relative terms, such as “beneath,” “below,” “under,” “lower,” “above,” “upper,” “over,” “higher,” “side” (e.g., as in “sidewall”), and the like, may be used herein for descriptive purposes, and, thereby, to describe one elements relationship to another element(s) as illustrated in the drawings. Spatially relative terms are intended to encompass different orientations of an apparatus in use, operation, and/or manufacture in addition to the orientation depicted in the drawings. For example, if the apparatus in the drawings is turned over, elements described as “below” or “beneath” other elements or features would then be oriented “above” the other elements or features. Thus, the exemplary term “below” can encompass both an orientation of above and below. Furthermore, the apparatus may be otherwise oriented (e.g., rotated 90 degrees or at other orientations), and, as such, the spatially relative descriptors used herein interpreted accordingly.

[0139] The terminology used herein is for the purpose of describing particular embodiments and is not intended to be limiting. As used herein, the singular forms, “a,” “an,” and “the” are intended to include the plural forms as well, unless the context clearly indicates otherwise. Moreover, the terms “comprises,” “comprising,” “includes,” and/or “including,” when used in this specification, specify the presence of stated features, integers, steps, operations, elements, components, and/or groups thereof, but do not preclude the presence or addition of one or more other features, integers, steps, operations, elements, components, and/or groups thereof. It is also noted that, as used herein, the terms “substantially,” “about,” and other similar terms, are used as terms of approximation and not as terms of degree, and, as such, are utilized to account for inherent deviations in

measured, calculated, and/or provided values that would be recognized by one of ordinary skill in the art.

[0140] Various exemplary embodiments are described herein with reference to sectional and/or exploded illustrations that are schematic illustrations of idealized exemplary embodiments and/or intermediate structures. As such, variations from the shapes of the illustrations as a result, for example, of manufacturing techniques and/or tolerances, are to be expected. Thus, exemplary embodiments disclosed herein should not necessarily be construed as limited to the particular illustrated shapes of regions, but are to include deviations in shapes that result from, for instance, manufacturing. In this manner, regions illustrated in the drawings may be schematic in nature and the shapes of these regions may not reflect actual shapes of regions of a device and, as such, are not necessarily intended to be limiting.

[0141] Unless otherwise defined, all terms (including technical and scientific terms) used herein have the same meaning as commonly understood by one of ordinary skill in the art to which this disclosure is a part. Terms, such as those defined in commonly used dictionaries, should be interpreted as having a meaning that is consistent with their meaning in the context of the relevant art and should not be interpreted in an idealized or overly formal sense, unless expressly so defined herein.

[0142] As used herein, a light emitting device or a light emitting diode according to exemplary embodiments may include a micro LED, which has a surface area less than about 10,000 square m as known in the art. In other exemplary embodiments, the micro LED’s may have a surface area of less than about 4,000 square rim, or less than about 2,500 square rim, depending upon the particular application.

[0143] FIG. 1 is a schematic plan view of a display apparatus according to an exemplary embodiment. FIG. 2 is a schematic cross-sectional view taken along line A-A of FIG. 1.

[0144] Referring to FIGS. 1 and 2, the display apparatus may include a substrate **51**, electrode pads **53a**, **53b**, **53c**, and **53d**, a first LED stack **23**, a second LED stack **33**, a third LED stack **43**, a first reflective electrode **25**, a second transparent electrode **35**, a third transparent electrode **45**, a first color filter **37**, a second color filter **47**, a first bonding layer **55**, a second bonding layer **65**, and a third bonding layer **75**. In addition, the display apparatus may include a plurality of connectors **59a**, **59b**, **59c**, **59d**, **69b**, **69c**, **69d**, **79c**, and **79d** and insulating layers **57**, **67**, and **77**. As used herein, a connector may be any type of structure, including through holes, vias, wires, lines, conductive material, and the like, that serves to electrically and/or mechanically connect two elements, such as layers.

[0145] The substrate **51** supports the LED stacks **23**, **33**, and **43**. In addition, the substrate **51** may have an internal circuit. For example, the substrate **51** may be a silicon substrate in which thin film transistors are formed. TFT substrates have been widely used in display fields, such as LCD display fields, for driving a display apparatus in an active matrix manner. Since TFT substrates are well known in the art, detailed descriptions of a structure of a TFT substrate will be omitted.

[0146] Although FIGS. 1 and 2 show one unit pixel disposed on the substrate **51**, a plurality of the unit pixels may be arranged on the substrate **51**, and the plurality of the unit pixels may be driven in an active matrix manner.

[0147] The electrode pads **53a**, **53b**, **53c**, and **53d** are exposed on the substrate **51**. Each of the electrode pads **53a**, **53b**, **53c**, and **53d** are connected to one of the subpixels of the unit pixel disposed on the substrate **51**, but the electrode pad **53d** is connected to each of the three subpixels. Each of the electrode pads **53a**, **53b**, **53c**, and **53d** may be connected to the internal circuit of the substrate **51**.

[0148] The first LED stack **23**, the second LED stack **33**, and the third LED stack **43** each include an n-type semiconductor layer, a p-type semiconductor layer, and an active layer interposed therebetween. The active layer may have a multi-quantum well structure.

[0149] The closer to the substrate **51**, the longer wavelength light may be emitted from the LED stacks. For example, the first LED stack **23** may be an inorganic light emitting diode configured to emit red light, the second LED stack **33** may be an inorganic light emitting diode configured to emit green light, and the third LED stack **43** may be an inorganic light emitting diode configured to emit blue light. The first LED stack **23** may include a GaInP-based well layer and the second LED stack **33** and the third LED stack **43** may include a GaInN-based well layer. However, the inventive concepts are not limited thereto, and when the pixel includes a micro LED, the first LED stack **23** may emit any one of red, green, and blue light, and the second and third LED stacks **33** and **43** may emit different one of red, green, and blue light, without adversely affecting operation due to small form factor of a micro LED.

[0150] The surfaces of each of the LED stacks **23**, **33**, and **43** may be an n-type semiconductor layer and a p-type semiconductor layer, respectively. Hereinafter, an upper surface and a lower surface of each of the first to third LED stacks **23**, **33**, and **43** will be described as an n-type and a p-type, respectively. However, the inventive concepts are not limited thereto, and the type of the upper surface and the lower surface of each of the LED stacks may be reversed or variously modified.

[0151] When the upper surface of the third LED stack **43** is an n-type, the upper surface of the third LED stack **43** may be surface textured by chemical etching or the like to form a roughened surface. The upper surfaces of the first LED stack **23** and the second LED stack **33** may also be subjected to surface texturing. However, when the second LED stack **33** emits green light, since green light has higher visibility than red light and blue light, it may be preferable to increase light emitting efficiency of the first LED stack **23** and the third LED stack **43** to the greater extent than that of the second LED stack **33**. As such, the first LED stack **23** and the third LED stack **43** may be surface textured to improve light extraction efficiency without surface texturing the second LED stack **33**. In this manner, light intensities of red light, green light, and the blue light may be balanced and adjusted to have substantially similar levels.

[0152] The first LED stack **23** is disposed close to the support substrate **51**, the second LED stack **33** is disposed on the first LED stack **23**, and the third LED stack **43** is disposed on the second LED stack **33**. Since the first LED stack **23** may emit light having a longer wavelength than the second and third LED stacks **33** and **43**, the light generated from the first LED stack **23** may be transmitted through the second and third LED stacks **33** and **43** and be emitted to the outside. In addition, since the second LED stack **33** may emit light having a longer wavelength than the third LED

stack **43**, the light generated from the second LED stack **33** may be transmitted through the third LED stack **43** and be emitted to the outside.

[0153] The first reflective electrode **25** is in ohmic contact with the p-type semiconductor layer of the first LED stack **23** and reflects the light generated from the first LED stack **23**. For example, the first reflective electrode **25** may include an ohmic contact layer **25a** and a reflective layer **25b**.

[0154] The ohmic contact layer **25a** is partially in contact with the p-type semiconductor layer. In order to prevent absorption of light by the ohmic contact layer **25a**, the ohmic contact layer **25a** may be formed in a predetermined area. For example, the ohmic contact layer **25a** may be disposed near an edge of the first LED stack **23** and may be arranged substantially in an annular shape. A contact area of the ohmic contact layer **25a** with respect to the first LED stack **23** may be 25% or less, or may be 10% or less in some exemplary embodiments. Even though the contact area of the ohmic contact layer **25a** is relatively small, when an area of the first LED stack **23** is about 200 μm or less in size, a current may be evenly distributed in the first LED stack **23**. The ohmic contact layer **25a** may be formed of transparent conductive oxides or Au alloys, such as Au(Zn) or Au(Be).

[0155] The reflective layer **25b** may cover the ohmic contact layer **25a** and the lower surface of the first LED stack **23**. However, as shown in FIG. 1, the reflective layer **25b** exposes the lower surface of the first LED stack **23** in regions around where the connectors **59a**, **59b**, **59c**, and **59d** are to be formed. More particularly, the reflective layer **25b** may expose the lower surface of the first LED stack **23** in a region surrounded by the ohmic contact layer **25a**. The reflective layer **25b** may include a reflective metal layer formed of Al, Ag, or others. In addition, the reflective layer **25b** may include a metal adhesion layer formed of Ti, Ta, Ni, Cr, or others on upper and lower surfaces of the reflective metal layer in order to improve adhesion of the reflective metal layer. The reflective layer **25b** may be formed of a metal layer, which has a high reflectance to light generated from the first LED stack **23**, for example, red light. Meanwhile, the reflective layer **25b** may have a relatively low reflectance to light generated from the second LED stack **33** or the third LED stack **43**, for example, green light or blue light. Therefore, the reflective layer **25b** may reduce light interference by absorbing light generated from the second and third LED stacks **33** and **43** that is emitted toward the support substrate **51**. Au has high reflectance to red light, and low reflectance to green light or blue light, and thus, may be used to form the reflective layer **25b** disposed on the first LED stack **23**.

[0156] The second transparent electrode **35** is in ohmic contact with the p-type semiconductor layer of the second LED stack **33**. The second transparent electrode **35** may be formed of a metal layer or conductive oxide layer transparent to red light and green light. The third transparent electrode **45** is in ohmic contact with the p-type semiconductor layer of the third LED stack **43**. The third transparent electrode **45** may be formed of a metal layer or conductive oxide layer transparent to red light, green light, and blue light. The second transparent electrode **35** and the third transparent electrode **45** may be in ohmic contact with the p-type semiconductor layer of each of the LED stacks to assist current distribution. Examples of the conductive oxide layer used for the second and third transparent electrodes **35** and **45** may include SnO_2 , InO_2 , ITO, ZnO, IZO or others.

[0157] The first color filter 37 may be disposed between the first LED stack 23 and the second LED stack 33. In addition, the second color filter 47 may be disposed between the second LED stack 33 and the third LED stack 43. The first color filter 37 may transmit light generated from the first LED stack 23 and reflects the light generated from the second LED stack 33. The second color filter 47 may transmit light generated from the first and second LED stacks 23 and 33 and reflect light generated from the third LED stack 43. As such, light generated from the first LED stack 23 may be emitted to the outside through the second LED stack 33 and the third LED stack 43, and light generated from the second LED stack 33 may be emitted to the outside through the third LED stack 43. Further, it may be possible to prevent light generated from the second LED stack 33 from being incident to the first LED stack 23 and being lost, or to prevent light generated from the third LED stack 43 from being incident to the second LED stack 33 and being lost.

[0158] In some exemplary embodiments, the first color filter 37 may also reflect light generated from the third LED stack 43.

[0159] The first and second color filters 37 and 47 may be, for example, a low pass filter through which only a low wavelength region of light, e.g., light in a long wavelength region, a band pass filter through which only a certain wavelength region of light passes, or a band stop filter only blocking a certain wavelength region of light. More particularly, the first and second color filters 37 and 47 may be formed by alternately stacking insulating layers having different refractive indices. For example, the color filters may be formed by alternately stacking TiO_2 and SiO_2 . The first and second color filters 37 and 47 may include a distributed Bragg reflector (DBR). A stop band in the distributed Bragg reflector may be controlled by adjusting the thicknesses of TiO_2 and SiO_2 . The low pass filter and the band pass filter may also be formed by alternately stacking insulating layers having different refractive indices one above another.

[0160] The first bonding layer 55 couples the first LED stack 23 to the substrate 51. As shown in the drawings, the first reflective electrode 25 may be in contact with the first bonding layer 55. The first bonding layer 55 may be transmissive or non-transmissive.

[0161] The second bonding layer 65 couples the second LED stack 33 to the first LED stack 23. As shown in the drawings, the second bonding layer 65 may be in contact with the first LED stack 23 and the first color filter 37. The second bonding layer 65 transmits light generated from the first LED stack 23. The second bonding layer 65 may be formed of, for example, spin-on-glass having light transmitting property.

[0162] The third bonding layer 75 couples the third LED stack 43 to the second LED stack 33. As shown in the drawings, the third bonding layer 75 may be in contact with the second LED stack 33 and the second color filter 47. However, the inventive concepts are not limited thereto, and a transparent conductive layer may be disposed on the second LED stack 33. The third bonding layer 75 transmits the light generated from the first LED stack 23 and the second LED stack 33. The third bonding layer 75 may be formed of, for example, spin-on-glass having light transmitting property.

[0163] The bonding layers 55, 65, and 75 may be formed by forming transparent organic layers or transparent inorganic layer on each of the two objects to be bonded, and then bonding the objects with each other. Examples of an organic layer may include SU8, poly(methyl methacrylate) (PMMA), polyimide, parylene, benzocyclobutene (BCB), or others. Examples of an inorganic layer may include Al_2O_3 , SiO_2 , SiN_x , or others. The organic layers may be bonded at high vacuum and high pressure. Surfaces of the inorganic layers may be planarized by, for example, a chemical mechanical polishing (CMP), and then surface energy is lowered by plasma and the like, resulting in bonding at high vacuum.

[0164] A first-1 connector 59d electrically connects the first reflective electrode 25 and the electrode pad 53d to each other. As such, the first-1 connector 59d is electrically connected to the lower surface of the first LED stack 23. As shown in the drawings, the first-1 connector 59d may pass through the first LED stack 23. However, the inventive concepts are not limited thereto, and the first-1 connector 59d may be formed on a side surface of the first LED stack 23. The insulating layer 57 is interposed between the first-1 connector 59d and the first LED stack 23, thereby preventing the first-1 connector 59d from being short-circuited to the upper surface of the first LED stack 23.

[0165] A first-2 connector 59a electrically connects the upper surface of the first LED stack 23 and the electrode pad 53a on the substrate 51 to each other. The first-2 connector 59a may be connected to the upper surface of the first LED stack 23, and may pass through the first LED stack 23 to be connected to the electrode pad 53a. The insulating layer 57 may be interposed between the first LED stack 23 and the first-2 connector 59a in order to prevent the first-2 connector 59a from being short-circuited to the lower surface of the first LED stack 23.

[0166] A first-3 connector 59b and a first-4 connector 59c may pass through the first LED stack 23 to be connected to each of the electrode pads 53b and 53c. The first-3 connector 59b and the first-4 connector 59c are insulated from the first LED stack 23, by the insulating layer 57 interposed between the first LED stack 23 and the connectors 59b and 59c.

[0167] The first-3 connector 59b and the first-4 connector 59c may function as an intermediate connector, or these configurations may be omitted in some exemplary embodiments.

[0168] A second-1 connector 69d is disposed to electrically connect the second transparent electrode 35 to the electrode pad 53d. The second-1 connector 69d is electrically connected to the lower surface of the second LED stack 33 through the second transparent electrode 35. As shown in the drawings, the second-1 connector 69d may pass through the second LED stack 33. However, the inventive concepts are not limited thereto, and the second-1 connector 69d may be formed on a side surface of the second LED stack 33. The insulating layer 67 is interposed between the second-1 connector 69d and the second LED stack 33, thereby preventing the second-1 connector 69d from being short-circuited to the upper surface of the second LED stack 33.

[0169] As shown in FIG. 2, the second-1 connector 69d may be connected to the first-1 connector 59d to be electrically connected to the electrode pad 53d. In this case, the first-1 connector 59d may function as an intermediate con-

necter. In addition, as shown in FIG. 2, the second-1 connector **69d** may be stacked on the first-1 connector **59d** in a vertical direction.

[0170] A second-2 connector **69b** is disposed to electrically connect the upper surface of the second LED stack **33** to the electrode pad **53b**. The second-2 connector **69b** may be connected to the upper surface of the second LED stack **33**, and may pass through the second LED stack **33**. As shown in the drawings, the second-2 connector **69b** may be connected to the first-3 connector **59b** to be electrically connected to the electrode pad **53b**. The second-2 connector **69b** may be directly connected to the electrode pad **53b**. In this case, the first-3 connector **59b** is omitted.

[0171] The insulating layer **67** may be interposed between the second LED stack **33** and the second-2 connector **69b** in order to prevent the second-2 connector **69b** from being short-circuited to the lower surface of the second LED stack **33**.

[0172] A second-3 connector **69c** may be disposed to pass through the second LED stack **33**. The second-3 connector **69c** may be electrically connected to the electrode pad **53c**, and may be connected to, for example, the first-4 connector **59c**. The second-3 connector **69c** is insulated from the second LED stack **33** by the insulating layer **67** interposed between the second LED stack **33** and the second-3 connector **69c**.

[0173] The second-3 connector **69c** may function as an intermediate connector, or these configurations may be omitted in some exemplary embodiments.

[0174] A third-1 connector **79d** is disposed to connect the third transparent electrode **45** and the electrode pad **53d** to each other. The third-1 connector **79d** is electrically connected to the lower surface of the third LED stack **43** through the third transparent electrode **45**. As shown in the drawings, the third-1 connector **79d** may pass through the third LED stack **43**. However, the inventive concepts are not limited thereto, and the third-1 connector **79d** may be formed on a side surface of the third LED stack **43**. The insulating layer **77** is interposed between the third-1 connector **79d** and the third LED stack **43**, thereby preventing the third-1 connector **79d** from being short-circuited to the upper surface of the third LED stack **43**.

[0175] As shown in FIG. 2, the third-1 connector **79d** may be connected to the second-1 connector **69d** to be electrically connected to the electrode pad **53d**. In this case, the second-1 connector **69d** and the first-1 connector **59d** may function as an intermediate connector. In addition, as shown in FIG. 2, the third-1 connector **79d** may be stacked on the second-1 connector **69d** in a vertical direction. Therefore, the first-1 connector **59d**, the second-1 connector **69d**, and the third-1 connector **79d** are electrically connected to one another and are stacked in a vertical direction. The connectors are disposed in an emission direction of light to absorb light. In a case where the connectors are disposed to be spaced apart from one another in a lateral direction, a light emission area may be decreased and cause increased light loss. However, the connectors according to an exemplary embodiment are stacked in a vertical direction to reduce loss of light generated from the first LED stack **23** and the second LED stack **33** by the connectors.

[0176] A third-2 connector **79c** is disposed to connect the upper surface of the third LED stack **43** and the electrode pad **53c** to each other. The third-2 connector **79c** may be connected to the upper surface of the third LED stack **43** and

may pass through the third LED stack **43**. As shown in the drawings, the third-2 connector **79c** may be connected to the second-3 connector **69c** to be electrically connected to the electrode pad **53c**. The third-2 connector **79c** may be directly connected to the electrode pad **53c**. In this case, the second-3 connector **69c** may be omitted.

[0177] Meanwhile, the insulating layer **77** may be interposed between the third LED stack **43** and the third-2 connector **79c** in order to prevent the third-2 connector **79c** from being short-circuited to the lower surface of the third LED stack **43**.

[0178] As shown in the drawings, the third-2 connector **79c**, the second-3 connector **69c**, and the first-4 connector **59c** may be stacked in a vertical direction, which may reduce loss of light.

[0179] To prevent light interference between the pixels due to light emission from the first LED stack **23**, the second LED stack **33**, and the third LED stack **43** to the side surfaces thereof, a light reflective layer or a light blocking material layer may be formed to cover side surfaces of the first to third LED stacks **23**, **33**, and **43**. Examples of the light reflective layer may include a distributed Bragg reflector, or an insulating layer formed of SiO₂ with a reflective metal layer or a highly reflective organic layer deposited on the insulating layer. As the light blocking layer, for example, black epoxy may be used. The light blocking materials prevent light interference between light emitting elements to increase a contrast ratio of an image.

[0180] According to an exemplary embodiment, the first LED stack **23** is electrically connected to the electrode pads **53d** and **53a**, the second LED stack **33** is electrically connected to the electrode pads **53d** and **53b**, and the third LED stack **43** is electrically connected to the electrode pads **53d** and **53c**. As such, anodes of the first LED stack **23**, the second LED stack **33**, and the third LED stack **43** are commonly and electrically connected to the electrode pad **53d**, and cathodes thereof are electrically connected to the electrode pads **53a**, **53b**, and **53c** different from one another, respectively. Therefore, the first to third LED stacks **23**, **33**, and **43** may be independently driven. Further, these LED stacks **23**, **33**, and **43** may be disposed on the thin film transistor substrate **51** and may be electrically connected to the internal circuit of the substrate **51** to be driven in an active matrix manner.

[0181] FIGS. 3A, 3B, 4A, 4B, 5A, 5B, 6A, 6B, 7A, 7B, 8A, 8B, 9A, 9B, 10A, 10B, 11A, 11B, 12A, 12B, 13A, 13B, 14A, 14B, 15A, 15B, 16A, and 16B are schematic plan views and schematic cross-sectional views illustrating a method of manufacturing a display apparatus according to an exemplary embodiment of the present disclosure. In the drawings, each plan view corresponds to the plan view of FIG. 1, and each cross-sectional view is taken along line A-A of FIG. 1.

[0182] First, referring to FIGS. 3A and 3B, a first LED stack **23** is grown on a first substrate **21**. The first substrate **21** may be, for example, a GaAs substrate. In addition, the first LED stack **23** is formed of AlGaInP-based semiconductor layers, and includes an n-type semiconductor layer, an active layer, and a p-type semiconductor layer.

[0183] An ohmic contact layer **25a** and a reflective layer **25b** are formed on the first LED stack **23** to form a first reflective electrode **25**. The ohmic contact layer **25a** may be formed by using lift-off technique or the like, and may be formed to be disposed near an edge of the first LED stack **23**.

As shown in the drawings, the ohmic contact layer 25a may be formed to have substantially an annular shape.

[0184] The reflective layer 25b covers the ohmic contact layer 25a and also covers the first LED stack 23. The reflective layer 25b may be formed to expose each of the edges of the first LED stack 23. More particularly, the reflective layer 25b may have an opening 25h exposing the first LED stack 23 with the ohmic contact layer 25a. The reflective layer 25b may be, for example, formed of Au and may be formed by using lift-off technique or the like.

[0185] Referring to FIGS. 4A and 4B, a second LED stack 33 is grown on a second substrate 31, and a second transparent electrode 35 and a first color filter 37 are formed on the second LED stack 33. The second LED stack 33 may be formed of gallium nitride-based semiconductor layers and may include a GaInN-based well layer. The second substrate 31, on which gallium nitride-based semiconductor layers may be grown, is different from the first substrate 21. A composition ratio of GaInN may be determined such that the second LED stack 33 may emit green light. Meanwhile, the second transparent electrode 35 is in ohmic contact with a p-type semiconductor layer.

[0186] Referring to FIGS. 5A and 5B, a third LED stack 43 is grown on a third substrate 41, and a third transparent electrode 45 and a second color filter 47 are formed on the third LED stack 43. The third LED stack 43 may be formed of gallium nitride-based semiconductor layers and may include a GaInN-based well layer. The third substrate 41, on which gallium nitride-based semiconductor layers may be grown, is different from the first substrate 21. A composition ratio of GaInN may be determined such that the third LED stack 43 may emit blue light. Meanwhile, the third transparent electrode 45 is in ohmic contact with a p-type semiconductor layer.

[0187] The first color filter 37 and the second color filter 47 are substantially the same those as described with reference to FIG. 1, therefore detailed descriptions thereof will be omitted to avoid redundancy.

[0188] Referring to FIGS. 6A and 6B, electrode pads 53a, 53b, 53c, and 53d are formed on a substrate 51. The substrate 51 may be a substrate formed of Si, having thin film transistors therein. Each of the electrode pads 53a, 53b, 53c, and 53d corresponding to one pixel area may be disposed in each of the four edge regions of the substrate 51.

[0189] The first LED stack 23, the second LED stack 33, the third LED stack 43, and the electrode pads 53a, 53b, 53c, and 53d are separately formed on different substrates, and the forming sequence thereof is not particularly limited.

[0190] Referring to FIGS. 7A and 7B, the first LED stack 23 is coupled onto the substrate 51 via a first bonding layer 55. The first bonding layer 55 may be disposed on the substrate 51, and the first reflective electrode 25 is disposed to face the substrate 51 so that the first reflective electrode 25 is bonded to the first bonding layer 55. Alternatively, bonding material layers may be formed on each of the substrate 51 and the first LED stack 23, and then the first LED stack 23 may be coupled to the substrate 51 by bonding the bonding material layers each other. Meanwhile, the first substrate 21 may be removed from the first LED stack 23 by chemical etching, or the like. As such, the n-type semiconductor layer of the first LED stack 23 is exposed on the upper surface. The exposed n-type semiconductor layer may be subjected to surface texturing.

[0191] Referring to FIGS. 8A and 8B, the first LED stack 23 is patterned to expose a part of the first reflective electrode 25. To avoid damages of the reflective layer 25b, the ohmic contact layer 25a may be exposed. In addition, the first LED stack 23 and the first bonding layer 55 are patterned to form openings for exposing the electrode pads 53a, 53b, 53c, and 53d.

[0192] Referring FIGS. 9A and 9B, an insulating layer 57 is formed to cover side surfaces of the first LED stack 23 in the openings. The insulating layer 57 may also partially cover upper surfaces of the first LED stack 23. The insulating layer 57 is formed to expose the first reflective electrode 25 and the electrode pads 53a, 53b, 53c, and 53d.

[0193] Referring FIGS. 10A and 10B, connectors 59a, 59b, 59c, and 59d are formed, which may be connected to the exposed electrode pads 53a, 53b, 53c, and 53d, respectively. A first-1 connector 59d is connected to the first reflective electrode 25 and also to the electrode pad 53d. Therefore, a lower surface of the first LED stack 23 and the electrode pad 53d are electrically connected to each other by the first-1 connector 59d. In addition, a first-2 connector 59a is connected to the upper surface of the first LED stack 23 and also to the electrode pad 53a. Therefore, the upper surface of the first LED stack 23 and the electrode pad 53a are electrically connected to each other by the first-2 connector 59a. A first-3 connector 59b and a first-4 connector 59c are insulated from the first LED stack 23 by the insulating layer 57.

[0194] Referring to FIGS. 11A and 11B, the second LED stack 33 of FIGS. 4A and 4B is coupled onto the first LED stack 23, on which the first-1, first-2, first-3, and first-4 connectors 59d, 59a, 59b, and 59c are formed, via a second bonding layer 65. The first color filter 37 is bonded to the second bonding layer 65 and disposed to face the first LED stack 23. The second bonding layer 65 may be disposed on the first LED stack 23 in advance. The first color filter 37 may be bonded to the second bonding layer 65 and disposed to face the second bonding layer 65 and. Alternatively, the bonding material layers may be formed on each of the first LED stack 23 and the first color filter 37, and the bonding material layers are bonded to each other to couple the second LED stack 33 to the first LED stack 23. Meanwhile, the second substrate 31 may be separated from the second LED stack 33 by using laser lift-off, chemical lift-off techniques, or others. Therefore, the n-type semiconductor layer of the second LED stack 33 is exposed. The exposed n-type semiconductor layer may be subjected to surface texturing by chemical etching or the like. However, the step of surface texturing on the second LED stack 33 may be omitted in some exemplary embodiments.

[0195] Referring to FIGS. 12A and 12B, the second LED stack 33 is patterned to expose the second transparent electrode 35, and the exposed second transparent electrode 35, the first color filter 37, and the second bonding layer 65 are etched to form openings for exposing the first-1 connector 59d. In addition, the openings for exposing the first-3 connector 59b and the first-4 connector 59c may be formed together.

[0196] Referring FIGS. 13A and 13B, an insulating layer 67 covering sides of the exposed openings is formed. The insulating layer 67 exposes the second transparent electrode 35 and also exposes the first-1 connector 59d, the first-3 connector 59b, and the first-4 connector 59c.

[0197] A second-1 connector **69d**, a second-2 connector **69b**, and a second-3 connector **69c** are formed in the openings. The second-1 connector **69d** electrically connects the second transparent electrode **35** and the first-1 connector **59d** to each other and is insulated from the upper surface of the second LED stack **33** by the insulating layer **67**. The second-2 connector **69b** is connected to the upper surface of the second LED stack **33** and to the first-3 connector **59b**. The second-2 connector **69b** is electrically connected to the electrode pad **53b** through the first-3 connector **59b**. The second-2 connector **69b** is insulated from the lower surface of the second LED stack **33** and the second transparent electrode **35** by the insulating layer **67**.

[0198] Meanwhile, the second-3 connector **69c** is connected to the first-4 connector **59c** and is insulated from the second LED stack **33** and the second transparent electrode **35** by the insulating layer **67**.

[0199] Referring to FIGS. **14A** and **14B**, the third LED stack **43** of FIGS. **5A** and **5B** is coupled onto the second LED stack **33**, on which the second-1, second-2, and second-3 connectors **69d**, **69b**, and **69c** are formed via a third bonding layer **75**. The second color filter **47** is bonded to the third bonding layer **75** and disposed to face the second LED stack **33**. The third bonding layer **75** may be disposed on the second LED stack **33** in advance, and the second color filter **47** may be bonded to the third bonding layer **75** and disposed to face the third bonding layer **75**. Alternatively, the bonding material layers may be formed on each of the second LED stack **33** and the second color filter **47**, and the bonding material layers to be bonded to each other to bond the third LED stack **43** to the second LED stack **33**. Meanwhile, the third substrate **41** may be separated from the third LED stack **43** by using laser lift-off, chemical lift-off techniques, or others. As such, the n-type semiconductor layer of the third LED stack **43** is exposed. The exposed n-type semiconductor layer may be subjected to surface texturing by chemical etching or the like.

[0200] Referring to FIGS. **15A** and **15B**, the third LED stack **43** is patterned to expose the third transparent electrode **45**, and the exposed third transparent electrode **45**, the second color filter **47**, and the third bonding layer **75** are etched to form openings for exposing the second-1 connector **69d**. In addition, the openings for exposing the second-3 connector **69c** may be formed together.

[0201] Referring to FIGS. **16A** and **16B**, an insulating layer **77** covering sides of the exposed openings is formed. The insulating layer **77** exposes the third transparent electrode **45**, and also exposes the second-1 connector **69d** and the second-3 connector **69c**.

[0202] A third-1 connector **79d** and a third-2 connector **79c** are formed in the openings. The third-1 connector **79d** electrically connects the third transparent electrode **45** and the second-connector **69d** to each other, and is insulated from the upper surface of the third LED stack **43** by the insulating layer **77**. The third-2 connector **79c** is connected to the upper surface of the third LED stack **43** and to the second-3 connector **69c**. The third-2 connector **79c** is electrically connected to the electrode pad **53c** through the second-3 connector **69c** and the first-4 connector **59c**. The third-2 connector **79c** is insulated from the lower surface of the third LED stack **43** and the third transparent electrode **45** by the insulating layer **77**.

[0203] According to an exemplary embodiment, a unit pixel having anodes of the first to third LED stacks **23**, **33**,

and **43** commonly and electrically connected to one another and cathodes thereof independently connected may be provided.

[0204] Although a method of manufacturing one unit pixel has been described above according to an exemplary embodiment, a display apparatus may include a plurality of unit pixels arranged on the substrate **51** in a matrix form. The unit pixels are spaced apart from each other. In this case, regions of the first to third LED stacks **23**, **33**, and **43** each corresponding to the unit pixels may be isolated, in advance, from one another on the substrates **21**, **31**, and **41**. Alternatively, when each of the LED stacks **23**, **33**, and **43** is patterned after being bonded onto the substrate **51**, the regions of the LED stacks may be isolated into regions corresponding to each pixel region. Accordingly, a display apparatus having a plurality of unit pixels on the substrate **51** according to an exemplary embodiment may obviate the need of individually mount pixels having a small size.

[0205] Further, in order to prevent light interference between pixels, a light reflective layer or a light blocking material layer covering sides of the pixels may be added. Examples of the light reflective layer may include a distributed Bragg reflector, or an insulating layer formed of SiO₂ with a reflective metal layer or a highly reflective organic layer deposited on the insulating layer. As the light blocking layer, for example, black epoxy may be used. The light blocking materials prevent light interference between light emitting elements to increase a contrast ratio of an image.

[0206] FIG. **17** is a schematic plan view of a display apparatus according to another exemplary embodiment. FIG. **18** is a schematic cross-sectional view taken along line B-B of FIG. **17**.

[0207] Referring to FIGS. **17** and **18**, the display apparatus according to an exemplary embodiment is generally similar to the display apparatus described with reference to FIGS. **1** and **2**, except that cathodes of the first to third LED stacks **23**, **33**, and **43** are commonly and electrically connected to one another, and anodes thereof are individually connected.

[0208] In particular, a first-1 connector **159d** electrically connects the first reflective electrode **25** to an electrode pad **153d**. A second-1 connector **169a** electrically connects the second transparent electrode **35** to an electrode pad **153a**, and a third-1 connector **179b** electrically connects the third transparent electrode **45** to an electrode pad **153b**.

[0209] In addition, a first-2 connector **159c** is connected to the upper surface of the first LED stack **23** and an electrode pad **153c**. A second-2 connector **169c** is connected to the upper surface of the second LED stack **33** and the first-2 connector **159c**. A third-2 connector **179c** is connected to the upper surface of the third LED stack **43** and the second-2 connector **169c**. As shown in the drawings, the first-2, second-2, and third-2 connectors **159c**, **169c**, and **179c** may be stacked in a vertical direction. In addition, the third-2 connector **179c** may be connected to the electrode pad **153b** through intermediate connectors **169b** and **159b**, and the connectors **159b**, **169b**, and **179b** may also be stacked in a vertical direction.

[0210] FIG. **19** is a schematic circuit diagram of a display apparatus according to an exemplary embodiment.

[0211] Referring to FIG. **19**, a driving circuit according to an exemplary embodiment includes two or more transistors Tr1 and Tr2 and capacitors. When power is connected to select lines Vrow1 to Vrow3 and a data voltage is applied to data lines Vdata1 to Vdata3, a voltage is applied to the

corresponding light emitting diode. Charges are charged to the corresponding capacitor depending on values of the Vdata1 to Vdata3. Since turn-on state of Tr2 is maintained by the charged voltage of the capacitor, a voltage of the capacitor may be maintained even if power is shut off, and a voltage may be applied to the light emitting diodes LED1 to LED3. In addition, a current flowing in LED1 to LED3 may be changed depending on values of the Vdata1 to Vdata3. A current may be constantly supplied through Vdd, and therefore continuous light emission is possible.

[0212] The transistors Tr1 and Tr2 and the capacitors may be formed in the substrate 51. Here, LED1 to LED3 correspond to the first to third LED stacks 23, 33, and 43, respectively, which are stacked as one pixel. Anodes of the first to third LED stacks are connected to the transistors Tr2 and cathodes thereof are grounded. According to an exemplary embodiment, the first to third LED stacks 23, 33, and 43 may be commonly connected one another to be grounded.

[0213] Although FIG. 19 shows a circuit diagram for driving an active matrix according to an exemplary embodiment, however, the inventive concepts are not limited thereto, and another circuit may be used. In addition, while each of the anodes of the LED1 to LED3 is described as being connected to different transistors Tr2 and cathodes thereof are described as being grounded, the anodes of the first to third LED stacks 23, 33, and 43 may be connected in common and each of cathodes thereof may be connected to different transistors in some exemplary embodiments.

[0214] FIG. 20 is a schematic plan view of a display apparatus according to an exemplary embodiment.

[0215] Referring to FIG. 20, the display apparatus includes a circuit board 201 and a plurality of light emitting devices 200.

[0216] The circuit board 201 may include a circuit for passive matrix driving or active matrix driving. In an exemplary embodiment, the circuit board 201 may include wires and resistors therein. In another exemplary embodiment, the circuit board 201 may include wires, transistors, and capacitors. The circuit board 201 may also have pads on the upper side thereof, such that the circuit disposed therein is allowed to be electrically connected.

[0217] A plurality of light emitting devices 200 are arranged on the circuit board 201. Each light emitting device 200 constitutes one pixel. The light emitting device 200 has electrode pads 281a, 281b, 281c, and 281d, and the electrode pads 281a, 281b, 281c, and 281d are electrically connected to the circuit board 201. The light emitting device 200 may also include a substrate 241 on the upper surface. As the light emitting devices 200 are spaced apart from each other, the substrates 241 disposed on the upper surfaces of the light emitting devices 200 are also spaced apart from each other.

[0218] The specific configuration of the light emitting device 200 will be described in detail with reference to FIGS. 21A and 21B. FIG. 21A is a schematic plan view of the light emitting device 200 according to an exemplary embodiment, and FIG. 21B is a cross-sectional view taken along line A-A of FIG. 21A. Although the electrode pads 281a, 281b, 281c, and 281d are shown as being arranged on the upper side, however, the inventive concepts are not limited thereto, and the light emitting device 200 may be flip-bonded on the circuit board 201 of FIG. 20, and in this case, the electrode pads 281a, 281b, 281c, and 281d will be arranged on the lower side.

[0219] Referring to FIGS. 21A and 21B, the light emitting device 200 includes the substrate 241, the electrode pads 281a, 281b, 281c, and 281d, a first LED stack 223, a second LED stack 233, a third LED stack 243, an insulating layer 271, a first reflective electrode 228, a second transparent electrode 235, a third transparent electrode 245, first ohmic electrodes 228, a first color filter 247, a second color filter 267, a first bonding layer 249, a second bonding layer 269, and an upper insulating layer 273.

[0220] The substrate 241 may support the LED stacks 223, 233, and 243. In addition, the substrate 241 may be a growth substrate for growing the third LED stack 243. For example, the substrate 241 may be a sapphire substrate or a gallium nitride substrate, in particular, a patterned sapphire substrate. The first, second, and third LED stacks are arranged on the substrate 241 in the order of the third LED stack 243, the second LED stack 233, and the first LED stack 223. Single third LED stack is disposed on one substrate 241, and thus, the light emitting device 200 has a single-chip structure of a single pixel. In some exemplary embodiments, the substrate 241 may be omitted and the lower surface of the third LED stack 243 may be exposed. In this case, a rough surface may be formed on the lower surface of the third LED stack 243 by surface texturing.

[0221] The first LED stack 223, the second LED stack 233, and the third LED stack 243 each include a first conductivity type semiconductor layer 223a, 233a, or 243a, a second conductivity type semiconductor layer 223b, 233b, or 243b, and an active layer interposed therebetween. In particular, the active layer may have a multiple quantum well structure.

[0222] The closer to the substrate 241, the shorter wavelength light may be emitted from the LED stack. For example, the first LED stack 223 may be an inorganic light emitting diode emitting red light, the second LED stack 233 may be an inorganic light emitting diode emitting green light, and the third LED stack 243 may be an inorganic light emitting diode emitting blue light. The first LED stack 223 may include a GaInP based well layer and the second LED stack 233 and the third LED stack 243 may include a GaInN based well layer. However, the inventive concepts are not limited thereto, and when the light emitting device 200 includes a micro LED, the first LED stack 223 may emit any one of red, green, and blue light, and second and third LED stacks 233 and 243 may emit different one of red, green, and blue light without adversely affecting operation due to small form factor of a micro LED.

[0223] The first conductivity type semiconductor layers 223a, 233a, and 243a of the respective LED stacks 223, 233, and 243 may be n-type semiconductor layers and the second conductivity type semiconductor layers 223b, 233b, and 243b of the respective LED stacks 223, 233, and 243 may be p-type semiconductor layers. The upper surface of the first LED stack 223 may be a p-type semiconductor layer 223b, the upper surface of the second LED stack 233 may be an n-type semiconductor layer 233a, and the upper surface of the third LED stack 243 may be a p-type semiconductor layer 243b. More particularly, according to an exemplary embodiment, the order of the semiconductor layers is reversed only in the second LED stack 233. The first LED stack 223 and the third LED stack 243 may have the first conductivity type semiconductor layers 223a and 243a with textured surfaces to improve light extraction efficiency. The second LED stack 233 may also have the first conductivity

type semiconductor layer **233a** with a textured surface, however, since the first conductivity type semiconductor layer **233a** is disposed farther away from the substrate **241** than the second conductivity type semiconductor layer **233b**, surface texturing may be less effective. More particularly, when the second LED stack **233** emits green light, the green light has higher visibility than red light or blue light. Therefore, it may be preferable to increase the luminous efficiency of the first LED stack **223** and the third LED stack **243** more than the luminous efficiency of the second LED stack **233**. In this manner, luminous intensities of red light, green light, and blue light can be adjusted or balanced to be kept at a similar level by applying surface texturing to the first LED stack **223** and the third LED stack **243** to improve light extraction efficiency while using the second LED stack **233** without or less surface texturing.

[0224] In the first LED stack **223** and the third LED stack **243**, the second conductivity type semiconductor layers **223b** and **243b** may be disposed on partial regions of the first conductivity type semiconductor layer **223a** and **243a**, and thus, the first conductivity type semiconductor layers **223a** and **243a** are partially exposed. Alternatively, in the case of the second LED stack **233**, the first conductivity type semiconductor layer **233a** and the second conductivity type semiconductor layer **233b** may be completely overlapped.

[0225] The first LED stack **223** is disposed apart from the substrate **241**, the second LED stack **233** is disposed below the first LED stack **223**, and the third LED stack **243** is disposed below the second LED stack **233**. The first LED stack **223** may emit light having a longer wavelength than the second and third LED stacks **233** and **243**, so that light generated in the first LED stack **223** is emitted to the outside through the second and third LED stacks **233** and **243** and the substrate **241**. In addition, the second LED stack **233** may emit light having a longer wavelength than the third LED stack **243**, so that light generated in the second LED stack **233** is emitted to the outside through the third LED stack **243** and the substrate **241**. However, the inventive concepts are not limited thereto. For example, when the light emitting device **200** includes a micro LED, the first LED stack **223** may emit any one of red, green, and blue light, and second and third LED stacks **233** and **243** may emit different one of red, green, and blue light without adversely affecting operation due to small form factor of a micro LED.

[0226] The insulating layer **271** is disposed on the first LED stack **223** and has an opening for exposing the second conductivity type semiconductor layer **223b** of the first LED stack **223**. The insulating layer **271** may have, for example, an opening having substantially an annular shape. The insulating layer **271** may be a transparent insulating layer having a lower refractive index than the first LED stack **223**.

[0227] The first reflective electrode **228** is in ohmic contact with the second conductivity type semiconductor layer **223b** of the first LED stack **223**, and reflects light generated in the first LED stack **223** toward the substrate **241**. The first reflective electrode **228** is disposed on the insulating layer **271** and is connected to the first LED stack **223** through the opening of the insulating layer **271**.

[0228] The first reflective electrode **228** may include an ohmic contact layer **228a** and a reflective layer **228b**. The ohmic contact layer **228a** is in partial contact with the second conductivity type semiconductor layer **223b**, for example, a p-type semiconductor layer. The ohmic contact layer **228a** may be formed in a predetermined area to prevent

the ohmic contact layer **228a** from absorbing light. The ohmic contact layer **228a** may be formed on the second conductivity type semiconductor layer **223b** exposed in the opening of the insulating layer **271**. The ohmic contact layer **228a** may be formed to have substantially an annular shape. The ohmic contact layer **228a** may be formed of a transparent conductive oxide, for example, an Au alloy, such as Au (Zn) or Au (Be).

[0229] The reflective layer **228b** covers the ohmic contact layer **228a** and the insulating layer **271**. When the reflective layer **228b** covers the insulating layer **271**, the first LED stack **223** may have a stacked structure of the first LED stack **223** having a relatively high refractive index, the insulating layer **271** having a relatively low refractive index, and the reflective layer **228b**, which may form an omnidirectional reflector. The reflective layer **228b** may include a reflective metal layer such as Al, Ag, or Au. In addition, the reflective layer **228b** may include an adhesive metal layer, such as Ti, Ta, Ni, or Cr on the upper and lower surfaces of the reflective metal layer to improve the adhesion of the reflective metal layer. Au is particularly suitable for the reflective layer **228b** formed in the first LED stack **223** because of its high reflectance to red light and its low reflectance to blue light or green light. The reflective layer **228b** may cover more than about 50% of the area of the first LED stack **223**, and may further cover most of the area to improve light efficiency.

[0230] The ohmic contact layer **228a** and the reflective layer **228b** may be formed of a metal layer containing Au. The reflective layer **228b** may be formed of a metal layer having high reflectance of light generated in the first LED stack **223**, for example, red light. The reflective layer **228b** may have a relatively low reflectance of light generated in the second LED stack **233** and the third LED stack **243**, for example, green light or blue light, and accordingly, light generated in the second and third LED stacks **233** and **243** and incident on the reflective layer **228b** may be absorbed to reduce optical interference.

[0231] A first ohmic electrode **226** is disposed on the exposed first conductivity type semiconductor layer **223a**, and is in ohmic contact with the first conductivity type semiconductor layer **223a**. The first ohmic electrode **226** may also be formed of a metal layer containing Au.

[0232] The second transparent electrode **235** is in ohmic contact with the second conductivity type semiconductor layer **233b** of the second LED stack **233**. As shown in the drawing, the second transparent electrode **235** is in contact with the lower surface of the second LED stack **233** between the second LED stack **233** and the third LED stack **243**. The second transparent electrode **235** may be formed of a metal layer or a conductive oxide layer which is transparent to red light and green light.

[0233] In addition, the third transparent electrode **245** is in ohmic contact with the second conductivity type semiconductor layer **243b** of the third LED stack **243**. The third transparent electrode **245** may be disposed between the second LED stack **233** and the third LED stack **243**, and is in contact with the upper surface of the third LED stack **243**. The third transparent electrode **245** may be formed of a metal layer or a conductive oxide layer which is transparent to red light and green light. The third transparent electrode **245** may also be transparent to blue light according to some exemplary embodiments. The second transparent electrode **235** and the third transparent electrode **245** may assist

current distribution by ohmic contact with the p-type semiconductor layer of each LED stack. Examples of the conductive oxide layer used for the second and third transparent electrodes **235** and **245** include SnO₂, InO₂, ITO, ZnO, IZO, or others.

[0234] The first color filter **247** may be disposed between the third transparent electrode **245** and the second LED stack **233**, and the second color filter **267** may be disposed between the second LED stack **233** and the first LED stack **223**. The first color filter **247** may transmit light generated in the first and second LED stacks **223** and **233** and reflect light generated in the third LED stack **243**. The second color filter **267** may transmit light generated in the first LED stack **223** and reflect light generated in the second LED stack **233**. Accordingly, light generated in the first LED stack **223** can be emitted to the outside through the second LED stack **233** and the third LED stack **243**, and light generated in the second LED stack **233** can be emitted to the outside through the third LED stack **243**. Furthermore, light generated in the second LED stack **233** may be prevented from being lost by being incident on the first LED stack **223**, or light generated in the third LED stack **243** may be prevented from being lost by being incident on the second LED stack **233**.

[0235] In some exemplary embodiments, the second color filter **267** may reflect light generated in the third LED stack **243**.

[0236] The first and second color filters **247** and **267** may be, for example, a low frequency range, such as a low pass filter that passes only a long wavelength band, a band pass filter that passes only a predetermined wavelength band, or a band stop filter that blocks only a predetermined wavelength band. In particular, the first and second color filters **247** and **267** may be formed by alternately stacking insulating layers having refractive indices different from each other, for example, may be formed by alternately stacking TiO₂ insulating layer and SiO₂ insulating layer. In particular, the first and second color filters **247** and **267** may include a distributed Bragg reflector (DBR). The stop band of the distributed Bragg reflector can be controlled by adjusting the thickness of TiO₂ and SiO₂ layers. The low pass filter and the band pass filter may also be formed by alternately stacking insulating layers having refractive indices different from each other.

[0237] The first bonding layer **249** couples the second LED stack **233** to the third LED stack **243**. The first bonding layer **249** covers the first color filter **247** and is bonded to the second transparent electrode **235**. For example, the first bonding layer **249** may be a transparent organic layer or a transparent inorganic layer. Examples of the organic layer include SU8, poly(methylmethacrylate) (PMMA), polyimide, parylene, and benzocyclobutene (BCB), examples of the inorganic layer include Al₂O₃, SiO₂, SiNx, or others. The organic layers may be bonded at a high vacuum and a high pressure, and the inorganic layers may be bonded under a high vacuum in a state in which the surface energy is lowered by using plasma or the like, after flattening the surface by a chemical mechanical polishing process, for example.

[0238] The second bonding layer **269** couples the second LED stack **233** to the first LED stack **223**. As shown in the drawing, the second bonding layer **269** may cover the second color filter **267** and be in contact with the first LED stack **223**. However, the inventive concepts are not limited thereto, and another layer such as a transparent electrode

layer may further be disposed to the lower surface of the first LED stack **223**. The second bonding layer **269** may be formed of substantially the same material as the first bonding layer **249** described above.

[0239] The upper insulating layer **273** covers the side surfaces and upper portions of the first, second, and third LED stacks **223**, **233**, and **243**. The upper insulating layer **273** may be formed of SiO₂, Si₃N₄, SOG, or others. Alternatively, the upper insulating layer **273** may contain a light reflecting material or a light blocking material to prevent optical interference with the adjacent light emitting device. For example, the upper insulating layer **273** may include a distributed Bragg reflector that reflects red light, green light, and blue light, or an SiO₂ layer with a reflective metal layer or a highly reflective organic layer deposited thereon. Alternatively, the upper insulating layer **273** may contain a black epoxy, as the light blocking material, for example. The light blocking material increases the contrast of an image by preventing optical interference between the light emitting devices.

[0240] The upper insulating layer **273** has openings for exposing the first ohmic electrode **26**, the first reflective electrode **228**, the second and third transparent electrodes **235** and **245**, and the second and third LED stacks **233** and **243**. Holes may be formed to pass through the first LED stack **223** and the second LED stack **233**, and the upper insulating layer **273** may cover the side walls of the holes while exposing the bottom surface of the holes.

[0241] The electrode pads **281a**, **281b**, **281c**, and **281d** are disposed above the first LED stack **223** and are electrically connected to the first, second, and third LED stacks **223**, **233**, and **243**. The electrode pads **281a**, **281b**, **281c**, and **281d** may be disposed on the upper insulating layer **273** and be connected to the first ohmic electrode **26**, the first reflective electrode **228**, the second and third transparent electrodes **235** and **245**, and the second and third LED stacks **233** and **243**, which are exposed through the holes h1, h2, h3, h4, and h5.

[0242] For example, the first electrode pad **281a** may be connected to the first ohmic electrode **26** through the hole h4 that passes through the upper insulating layer **273**. The first electrode pad **281a** is electrically connected to the first conductivity type semiconductor layer **223a** of the first LED stack **223**.

[0243] The second electrode pad **281b** may be connected to the first conductivity type semiconductor layer **233a** of the second LED stack **233** through the hole h3 that passes through the upper insulating layer **273** and the first LED stack **223**.

[0244] The third electrode pad **281c** may be electrically connected to the first conductivity type semiconductor layer **243a** of the third LED stack **243** through the hole h2 that passes through the upper insulating layer **273**, the first LED stack **223**, and the second LED stack **233**. The hole h2 may pass through the second conductivity type semiconductor layer **243b** of the third LED stack **243** and the active layer.

[0245] Meanwhile, the common electrode pad **281d** may be connected in common to the first reflective electrode **228**, the second transparent electrode **235**, and the third transparent electrode **245** through the holes h1 and h5. The hole h1 passes through the first LED stack **223** and the second LED stack **233** to expose the second transparent electrode **235** and the third transparent electrode **245**, and the hole h5 exposes the first reflective electrode **228**. Accordingly, the common

electrode pad **281d** is electrically connected in common to the second conductivity type semiconductor layer **223b** of the first LED stack **223**, the second conductivity type semiconductor layer **233b** of the second LED stack **233**, and the second conductivity type semiconductor layer **243b** of the third LED stack **243**. In addition, as shown in FIG. **21B**, the common electrode pad **281d** may be connected to the third LED stack **243** through the hole **h1** that passes through a hollow portion surrounded by the first reflective electrode **228**.

[0246] According to an exemplary embodiment, the first LED stack **223** is electrically connected to the electrode pads **281d** and **281a**, and the second LED stack **233** is electrically connected to the electrode pads **281d** and **281b**, and the third LED stack **243** is electrically connected to the electrode pads **281d** and **281c**. Accordingly, anodes of the first LED stack **223**, the second LED stack **233**, and the third LED stack **243** are electrically connected in common to the electrode pad **281d**, and cathodes thereof are electrically connected to the first, second, and third electrode pads **281a**, **281b**, and **281c**, respectively. Thus, the first, second, and third LED stacks **223**, **233**, and **243** can be independently driven.

[0247] FIGS. **22**, **23**, **24**, **25**, **26A**, **26B**, **27A**, **27B**, **28A**, **28B**, **29**, **30A**, **30B**, **31A**, **31B**, **32A**, **32B**, **33A**, **33B**, **34A**, **34B**, **35A** and **35B** are schematic plan views and cross-sectional views illustrating a method of manufacturing the light emitting device **200** according to an exemplary embodiment. In the drawings, each plan view corresponds to a plan view of FIG. **21A**, and each cross-sectional view is taken along line A-A of FIG. **21A**.

[0248] First, referring to FIG. **22**, the first LED stack **223** is grown on a first substrate **221**. The first substrate **221** may be a GaAs substrate, for example. The first LED stack **223** is formed of AlGaInP based semiconductor layers, and includes the first conductivity type semiconductor layer **223a**, the active layer, and the second conductivity type semiconductor layer **223b**. Here, the first conductivity type may be an n-type and the second conductivity type may be a p-type.

[0249] Referring to FIG. **23**, the second LED stack **233** is grown on a second substrate **231**, and the second transparent electrode **235** is formed on the second LED stack **233**. The second LED stack **233** is formed of gallium nitride based semiconductor layers, and may include the first conductivity type semiconductor layer **233a**, the active layer, and the second conductivity type semiconductor layer **233b**. The active layer may include a GaInN well layer. Here, the first conductivity type may be an n-type and the second conductivity type may be a p-type.

[0250] The second substrate **231** is a substrate on which a gallium nitride based semiconductor layer can be grown, and is different from the first substrate **221**. The composition ratio of the GaInN well layer may be determined so that the second LED stack **233** emits green light, for example. The second transparent electrode **235** is in ohmic contact with the second conductivity type semiconductor layer **233b**. The second transparent electrode **235** may be formed of a conductive oxide layer such as SnO₂, InO₂, ITO, ZnO, or IZO.

[0251] Referring to FIG. **24**, the third LED stack **243** is grown on a third substrate **241**, and the third transparent electrode **245** and the first color filter **247** are formed on the third LED stack **243**. The third LED stack **243** is formed of gallium nitride based semiconductor layers, and includes the

first conductivity type semiconductor layer **243a**, the active layer, and the second conductivity type semiconductor layer **243b**. The active layer may also include a GaInN well layer. Here, the first conductivity type may be an n-type and the second conductivity type may be a p-type.

[0252] The third substrate **241** is a substrate on which a gallium nitride based semiconductor layer can be grown, and is different from the first substrate **221**. The composition ratio of the GaInN well layer may be determined so that the third LED stack **243** emits blue light, for example. The third transparent electrode **245** is in ohmic contact with the second conductivity type semiconductor layer **243b**. The third transparent electrode **245** may be formed of a conductive oxide layer, such as SnO₂, InO₂, ITO, ZnO, or IZO.

[0253] Since the first color filter **247** is substantially the same as that described with reference to FIGS. **21A** and **21B**, detailed descriptions thereof will be omitted in order to avoid redundancy.

[0254] Referring to FIG. **25**, the second LED stack **233** of FIG. **223** is bonded onto the third LED stack **243** of FIG. **24**.

[0255] The first color filter **247** and the second transparent electrode **235** are bonded so as to face each other. For example, bonding material layers are formed on the first color filter **247** and the second transparent electrode **235**, respectively, and by bonding the first color filter **247** and the second transparent electrode **235**, the first bonding layer **249** may be formed. The bonding material layers may be, for example, a transparent organic layer or a transparent inorganic layer. Examples of the organic layer include SU8, poly(methylmethacrylate) (PMMA), polyimide, parylene, benzocyclobutene (BCB), or others, and examples of the inorganic layer include Al₂O₃, SiO₂, SiNx, or others. The organic layers may be bonded at a high vacuum and a high pressure, and the inorganic layers may be bonded under a high vacuum in a state in which the surface energy is lowered by using plasma or the like, after flattening the surface by a chemical mechanical polishing process, for example.

[0256] Then, the second substrate **231** is removed from the second LED stack **233** using techniques such as laser lift-off or chemical lift-off. Accordingly, the first conductivity type semiconductor layer **233a** of the second LED stack **233** is exposed from above. The surface of the exposed first conductivity type semiconductor layer **233a** may be textured.

[0257] Meanwhile, before coupling the first LED stack **223** to the second LED stack, a reflective electrode and an ohmic electrode are first formed on the first LED stack **223**, and the substrate **221** is removed using a carrier substrate. This will be described in more detail below with reference to FIGS. **26A**, **26B**, **27A**, **27B**, **28A**, **28B**, and **29**.

[0258] Referring to FIGS. **26A** and **26B**, the second conductivity type semiconductor layer **223b** of the first LED stack **223** of FIG. **22** is patterned to expose the first conductivity type semiconductor layer **223a**. A light emitting device region may have substantially a rectangular shape as shown in FIG. **26A**. Here, the second conductivity type semiconductor layer **223b** is removed in the vicinity of four corners in one light emitting device region. As shown in FIG. **26A**, all of the second conductivity type semiconductor layer **223b** may be removed in the vicinity of three corners, and a hole that passes through the second conductivity type semiconductor layer **223b** may be formed in the vicinity of one corner. Here, although one light emitting device region is shown, a plurality of light emitting device regions may be

provided on the substrate 241, and the second conductivity type semiconductor layer 223b may be patterned in each light emitting device region according to some exemplary embodiments.

[0259] Referring to FIGS. 27A and 27B, the first ohmic electrode 226 is formed in the vicinity of one corner. The first ohmic electrode 26 is in ohmic contact with the first conductivity type semiconductor layer 223a.

[0260] Then, the insulating layer 271 covering the first ohmic electrode 226 and the first LED stack 223 is formed and patterned to form an opening for exposing the second conductivity type semiconductor layer 223b. For example, SiO₂ is formed on the first LED stack 223, a photoresist is applied thereto, and then a photoresist pattern is formed using photolithography and development. Then, SiO₂ is patterned using the photoresist pattern as an etching mask to form the insulating layer 271 having an opening.

[0261] The opening may be formed around the hole that passes through the second conductivity type semiconductor layer 223b, and may surround the hole having substantially an annular shape.

[0262] Then, the ohmic contact layer 228a is formed in the opening of the insulating layer 271. The ohmic contact layer 228a may be formed using a lift-off technique or the like. The ohmic contact layer 228a may be formed to have substantially an annular shape along the shape of the opening.

[0263] Referring to FIGS. 28A and 28B, after the ohmic contact layer 228a is formed, the reflective layer 228b covering the ohmic contact layer 228a and the insulating layer 271 is formed. The reflective layer 228b may be formed using a lift-off technique or the like. The first reflective electrode 228 is formed by the ohmic contact layer 228a and the reflective layer 228b.

[0264] The first reflective electrode 228 may have a shape in which four corner portions are removed in one rectangular light emitting device region, as shown in the drawing. In particular, at one corner portion, the first reflective electrode 228 may have a hollow portion above a hole formed in the second conductivity type semiconductor layer 223b. Here, although one light emitting device region is shown, a plurality of light emitting device regions may be provided on the substrate 221, and the first reflective electrode 228 may be formed in each light emitting device region according to some exemplary embodiments.

[0265] Referring to FIG. 29, the carrier substrate 251 is bonded onto the first LED stack 223 of FIGS. 28A and 28B. The first reflective electrode 228 is disposed to face the carrier substrate 251, and the first LED stack 223 may be bonded to the carrier substrate 251 using the adhesive layer 253. Then, the substrate 221 is removed from the first LED stack 223. Accordingly, the first conductivity type semiconductor layer 223a is exposed. The surface of the exposed first conductivity type semiconductor layer 223a may be textured to improve light extraction efficiency, so that a roughened surface or a light extracting structure may be formed on the surface of the first conductivity type semiconductor layer 223a.

[0266] Hereinafter, with reference to FIG. 25, a method of manufacturing the light emitting device 200 by bonding the first LED stack 223 onto the second LED stack 233 will be described.

[0267] Referring to FIGS. 30A and 30B, first, the second color filter 267 is formed on the exposed first conductivity

type semiconductor layer 233a of the second LED stack 233 of FIG. 25. Since the second color filter 267 is substantially the same as that described with reference to FIGS. 21A and 21B, detailed descriptions thereof will be omitted.

[0268] The first LED stack 223 is bonded onto the second LED stack 233. The second color filter 267 and the first LED stack 223 may be bonded to face each other. For example, bonding material layers are formed on the second color filter 267 and the first LED stack 223, respectively, and by bonding the second color filter 267 and the first LED stack 223, the second bonding layer 269 may be formed. The bonding material layers may be a transparent organic layer or a transparent inorganic layer as described above.

[0269] Then, the carrier substrate 251 and the adhesive layer 253 are removed. Accordingly, the first reflective electrode 228 is exposed.

[0270] Referring to FIGS. 31A and 31B, the insulating layer 271 is patterned to expose the first LED stack 223 around the first reflective electrode 228, and then the first LED stack 223, the second bonding layer 269, and the second color filter 269 are sequentially patterned to form holes h1, h2, and h3 through which the first conductivity type semiconductor layer 233a of the second LED stack 233 is exposed. Further, the second LED stack 233 is patterned so that the holes h1 and h2 pass through the second LED stack 233 to expose the second transparent electrode 235. The hole h3 is maintained to expose the first conductivity type semiconductor layer 233a of the second LED stack 233.

[0271] In addition, the insulating layer 271, the first LED stack 223, the second bonding layer 269, the second color filter 267, and the second LED stack 233 are sequentially removed so that the second transparent electrode 235 is exposed at edge portions of the light emitting device regions.

[0272] Referring to FIGS. 32A and 32B, the second transparent electrode 235, the first bonding layer 249, and the first color filter 247 are removed to expose the third transparent electrode 245 through the holes h1 and h2. The upper surface of the second transparent electrode 235 is partially exposed in the hole h1.

[0273] In addition, the second transparent electrode 235, the first bonding layer 249, and the first color filter 247 are also removed at the edge portions of the light emitting device regions to expose the third transparent electrode 245.

[0274] Referring to FIGS. 33A and 33B, the third transparent electrode 245 and the second conductivity type semiconductor layer 243b are patterned to expose the first conductivity type semiconductor layer 243a of the third LED stack 243 through the hole h2. The hole h1 is maintained to expose the third transparent electrode 245.

[0275] In addition, the third transparent electrode 245 and the third LED stack 243 are removed so that the substrate 241 is exposed at the edge portions of the light emitting device regions. The exposed regions of the substrate 241 may be dicing regions for dividing the light emitting devices.

[0276] As shown in FIG. 33B, the hole h1 is formed to pass through the hollow portion of the first reflective electrode 228 and exposes the second transparent electrode 235 and the second transparent electrode 245. The hole h2 passes through both the first and second LED stacks 223 and 233 and exposes the first conductivity type semiconductor layer 243a by passing through the second conductivity type semiconductor layer 243b. The hole h3 passes through the

first LED stack **223** and exposes the first conductivity type semiconductor layer **233a** of the second LED stack **233**.

[0277] Referring to FIGS. **34A** and **34B**, the upper insulating layer **273** is formed to cover side surfaces and an upper region of the first, second, and third LED stacks **223**, **233**, and **243**. The upper insulating layer **273** may be formed of a single layer or multiple layers of SiO₂, Si₃N₄, SOG, or others. Alternatively, the upper insulating layer **273** may contain a light reflecting material or a light blocking material to prevent optical interference between adjacent light emitting devices. For example, the upper insulating layer **273** may include a distributed Bragg reflector that reflects red light, green light, and blue light, or SiO₂ layer with a reflective metal layer or a highly reflective organic layer deposited thereon. Alternatively, the upper insulating layer **273** may contain a black epoxy, as the light blocking material, for example. The light blocking material may increase the contrast of an image by preventing optical interference between the light emitting devices. The distributed Bragg reflector may be formed, for example, by alternately depositing SiO₂ and TiO₂ layers.

[0278] Then, the upper insulating layer **273** is patterned using photolithography and etching techniques to form openings in the holes **h1**, **h2**, and **h3**, and openings **h4** and **h5** are further formed. The upper insulating layer **273** exposes the second transparent electrode **235** and the third transparent electrode **245** in the hole **h1**, and covers the sides of the first LED stack **223** and the second LED stack **233**. In addition, the upper insulating layer **273** covers the side wall in the hole **h2** while exposing the first conductivity type semiconductor layer **243a**. Further, the upper insulating layer **273** exposes the first conductivity type semiconductor layer **233a** of the second LED stack **233** in the hole **h3**. Meanwhile, the hole **h4** passes through the upper insulating layer **273** and the insulating layer **271** to expose the first ohmic electrode **226**, and the hole **h5** passes through the upper insulating layer **273** to expose the first reflective electrode **228**. The hole **h5** may be formed to have substantially an annular shape as shown in FIG. **34A**.

[0279] Referring to FIGS. **35A** and **35B**, the electrode pads **281a**, **281b**, **281c**, and **281d** are formed on the upper insulating layer **273**. The electrode pads **281a**, **281b**, **281c**, and **281d** include the first electrode pad **281a**, the second electrode pad **281b**, the third electrode pad **281c**, and the common electrode pad **281d**.

[0280] The common electrode pad **281d** is connected to the second transparent electrode **235** and the second transparent electrode **245** through the hole **h1**, and to the first reflective electrode **228** through the hole **h5**. Thus, the common electrode pad **281d** is electrically connected in common to the anodes of the first, second, and third LED stacks **223**, **233**, and **243**.

[0281] The first electrode pad **281a** is connected to the first ohmic electrode **226** through the hole **h4**, and electrically connected to the cathode of the first LED stack **223**, e.g., the first conductivity type semiconductor layer **223a**. Meanwhile, the second electrode pad **281b** is electrically connected to the cathode of the second LED stack **233**, e.g., the first conductivity type semiconductor layer **233a** through the hole **h3**, and the third electrode pad **281c** is electrically connected to the cathode of the third LED stack **243**, e.g., the first conductivity type semiconductor layer **243a** through the hole **h2**

[0282] Meanwhile, the electrode pads **281a**, **281b**, **281c**, and **281d** are electrically separated from each other, so that each of the first, second, and third LED stacks **223**, **233**, and **243** is electrically connected to two electrode pads, and is adapted to be independently driven.

[0283] Subsequently, the light emitting device **200** according to an exemplary embodiment is provided by dividing the substrate **241** into light emitting device regions. As shown in FIG. **35A**, the electrode pads **281a**, **281b**, **281c**, and **281d** may be disposed at four corners of each light emitting device **200**. In addition, the electrode pads **281a**, **281b**, **281c**, and **281d** may have substantially a rectangular shape, but are not limited thereto.

[0284] Although the substrate **241** is described above as being divided, according to some exemplary embodiments, the substrate **241** may be removed so that the surface of the exposed first conductivity type semiconductor layer **243** may be textured. The substrate **241** may be removed after bonding the first LED stack **223** on the second LED stack **233**, or may be removed after forming the electrode pads **281a**, **281b**, **281c**, and **281d**.

[0285] According to the exemplary embodiments, a light emitting device includes anodes of the first, second, and third LED stacks **223**, **233**, and **243** that are electrically connected in common, and cathodes thereof are independently connected. However, the inventive concepts are limited thereto, and for example, the anodes of the first, second, and third LED stacks **223**, **233**, and **243** may be independently connected to the electrode pads, and the cathodes may be electrically connected in common.

[0286] The light emitting device **200** may include the first, second, and third LED stacks **223**, **233**, and **243** to emit red, green, and blue light, and thus, may be used as a single pixel in a display apparatus. As described with reference to FIG. **20**, a display apparatus may be provided by aligning a plurality of light emitting devices **200** on the circuit board **201**. Since the light emitting device **200** includes the first, second, and third LED stacks **223**, **233**, and **243**, the area of the subpixel in one pixel may be increased. Further, the first, second, and third LED stacks **223**, **233**, and **243** may be mounted by mounting one light emitting device **200**, thereby reducing the number of mounting processes.

[0287] As described with reference to FIG. **20**, the light emitting devices **200** mounted on the circuit board **201** may be driven by a passive matrix method or an active matrix method.

[0288] FIG. **36** is a schematic cross-sectional view of a light emitting diode stack for a display according to an exemplary embodiment.

[0289] Referring to FIG. **36**, the light emitting diode stack **1000** includes a support substrate **1510**, a first LED stack **1230**, a second LED stack **1330**, a third LED stack **1430**, a reflective electrode **1250**, an ohmic electrode **1290**, a second-p transparent electrode **1350**, a third-p transparent electrode **1450**, an insulation layer **1270**, a first color filter **1370**, a second color filter **1470**, a first bonding layer **1530**, a second bonding layer **1550**, and a third bonding layer **1570**. In addition, the first LED stack **1230** may include an ohmic contact portion **1230a** for ohmic contact.

[0290] The support substrate **1510** supports the semiconductor stacks **1230**, **1330**, and **1430**. The support substrate **1510** may include a circuit on a surface thereof or therein,

but the inventive concepts are not limited thereto. The support substrate **1510** may include, for example, a Si substrate or a Ge substrate.

[0291] Each of the first LED stack **1230**, the second LED stack **1330**, and the third LED stack **1430** includes an n-type semiconductor layer, a p-type semiconductor layer, and an active layer interposed therebetween. The active layer may have a multi-quantum well structure.

[0292] For example, the first LED stack **1230** may be an inorganic light emitting diode configured to emit red light, the second LED stack **1330** may be an inorganic light emitting diode configured to emit green light, and the third LED stack **1430** may be an inorganic light emitting diode configured to emit blue light. The first LED stack **1230** may include a GaInP-based well layer, and each of the second LED stack **1330** and the third LED stack **1430** may include a GaInN-based well layer.

[0293] In addition, both surfaces of each of the first to third LED stacks **1230**, **1330**, **1430** are an n-type semiconductor layer and a p-type semiconductor layer, respectively. In the illustrated exemplary embodiment, each of the first to third LED stacks **1230**, **1330**, and **1430** has an n-type upper surface and a p-type lower surface. Since the third LED stack **1430** has an n-type upper surface, a roughened surface may be formed on the upper surface of the third LED stack **1430** through chemical etching. However, the inventive concepts are not limited thereto, and the semiconductor types of the upper and lower surfaces of each of the LED stacks can be alternatively arranged.

[0294] The first LED stack **1230** is disposed near the support substrate **1510**, the second LED stack **1330** is disposed on the first LED stack **1230**, and the third LED stack **1430** is disposed on the second LED stack **1330**. Since the first LED stack **1230** emits light having a longer wavelength than the second and third LED stacks **1330** and **1430**, light generated from the first LED stack **1230** can be emitted outside through the second and third LED stacks **1330** and **1430**. In addition, since the second LED stack **1330** emits light having a longer wavelength than the third LED stack **1430**, light generated from the second LED stack **1330** can be emitted outside through the third LED stack **1430**.

[0295] The reflective electrode **1250** forms ohmic contact with the p-type semiconductor layer of the first LED stack **1230**, and reflects light generated from the first LED stack **1230**. For example, the reflective electrode **1250** may include an ohmic contact layer **1250a** and a reflective layer **1250b**.

[0296] The ohmic contact layer **1250a** partially contacts the p-type semiconductor layer of the first LED stack **1230**. In order to prevent absorption of light by the ohmic contact layer **1250a**, a region in which the ohmic contact layer **1250a** contacts the p-type semiconductor layer may not exceed 50% of the total area of the p-type semiconductor layer. The reflective layer **1250b** covers the ohmic contact layer **1250a** and the insulation layer **1270**. As shown in FIG. 36, the reflective layer **1250b** may cover substantially the entire ohmic contact layer **1250a**, without being limited thereto. Alternatively, the reflective layer **1250b** may cover a portion of the ohmic contact layer **1250a**.

[0297] Since the reflective layer **1250b** covers the insulation layer **1270**, an omnidirectional reflector can be formed by the stacked structure of the first LED stack **1230** having a relatively high index of refraction, and the insulation layer **1270** and the reflective layer **1250b** having a relatively low

index of refraction. The reflective layer **1250b** may cover 50% or more of the area of the first LED stack **1230**, or most of the first LED stack **1230**, thereby improving luminous efficacy.

[0298] The ohmic contact layer **1250a** and the reflective layer **1250b** may be metal layers, which may include Au. The reflective layer **1250b** may be formed of a metal having relatively high reflectance with respect to light generated from the first LED stack **1230**, for example, red light. On the other hand, the reflective layer **1250b** may be formed of a metal having relatively low reflectance with respect to light generated from the second LED stack **1330** and the third LED stack **1430**, for example, green light or blue light, to reduce interference of light having been generated from the second and third LED stacks **1330** and **1430** and traveling toward the support substrate **1510**.

[0299] The insulation layer **1270** is interposed between the support substrate **1510** and the first LED stack **1230** and has openings that expose the first LED stack **1230**. The ohmic contact layer **1250a** is connected to the first LED stack **1230** in the openings of the insulation layer **1270**.

[0300] The ohmic electrode **1290** is disposed on the upper surface of the first LED stack **1230**. In order to reduce ohmic contact resistance of the ohmic electrode **1290**, the ohmic contact portion **1230a** may protrude from the upper surface of the first LED stack **1230**. The ohmic electrode **1290** may be disposed on the ohmic contact portion **1230a**.

[0301] The second-p transparent electrode **1350** forms ohmic contact with the p-type semiconductor layer of the second LED stack **1330**. The second-p transparent electrode **1350** may include a metal layer or a conductive oxide layer that is transparent to red light and green light.

[0302] The third-p transparent electrode **1450** forms ohmic contact with the p-type semiconductor layer of the third LED stack **1430**. The third-p transparent electrode **1450** may include a metal layer or a conductive oxide layer that is transparent to red light, green light, and blue light.

[0303] The reflective electrode **1250**, the second-p transparent electrode **1350**, and the third-p transparent electrode **1450** may assist in current spreading through ohmic contact with the p-type semiconductor layer of corresponding LED stack.

[0304] The first color filter **1370** may be interposed between the first LED stack **1230** and the second LED stack **1330**. The second color filter **1470** may be interposed between the second LED stack **1330** and the third LED stack **1430**. The first color filter **1370** transmits light generated from the first LED stack **1230** while reflecting light generated from the second LED stack **1330**. The second color filter **1470** transmits light generated from the first and second LED stacks **1230** and **1330**, while reflecting light generated from the third LED stack **1430**. As such, light generated from the first LED stack **1230** can be emitted outside through the second LED stack **1330** and the third LED stack **1430**, and light generated from the second LED stack **1330** can be emitted outside through the third LED stack **1430**. Further, light generated from the second LED stack **1330** may be prevented from entering the first LED stack **1230**, and light generated from the third LED stack **1430** may be prevented from entering the second LED stack **1330**, thereby preventing light loss.

[0305] In some exemplary embodiments, the first color filter **1370** may reflect light generated from the third LED stack **1430**.

[0306] The first and second color filters **1370** and **1470** may be, for example, a low pass filter that transmits light in a low frequency band, that is, in a long wavelength band, a band pass filter that transmits light in a predetermined wavelength band, or a band stop filter that prevents light in a predetermined wavelength band from passing there-through. In particular, each of the first and second color filters **1370** and **1470** may include a distributed Bragg reflector (DBR). The distributed Bragg reflector may be formed by alternately stacking insulation layers having different indices of refraction one above another, for example, TiO_2 and SiO_2 . In addition, the stop band of the distributed Bragg reflector can be controlled by adjusting the thicknesses of TiO_2 and SiO_2 layers. The low pass filter and the band pass filter may also be formed by alternately stacking insulation layers having different indices of refraction one above another.

[0307] The first bonding layer **1530** couples the first LED stack **1230** to the support substrate **1510**. As shown in FIG. **36**, the reflective electrode **1250** may adjoin the first bonding layer **1530**. The first bonding layer **1530** may be a light transmissive or opaque layer.

[0308] The second bonding layer **1550** couples the second LED stack **1330** to the first LED stack **1230**. As shown in FIG. **36**, the second bonding layer **1550** may adjoin the first LED stack **1230** and the first color filter **1370**. The ohmic electrode **1290** may be covered by the second bonding layer **1550**. The second bonding layer **1550** transmits light generated from the first LED stack **1230**. The second bonding layer **1550** may be formed of, for example, light transmissive spin-on-glass.

[0309] The third bonding layer **1570** couples the third LED stack **1430** to the second LED stack **1330**. As shown in FIG. **36**, the third bonding layer **1570** may adjoin the second LED stack **1330** and the second color filter **1470**. However, the inventive concepts are not limited thereto. For example, a transparent conductive layer may be disposed on the second LED stack **1330**. The third bonding layer **1570** transmits light generated from the first LED stack **1230** and the second LED stack **1330**. The third bonding layer **1570** may be formed of, for example, light transmissive spin-on-glass.

[0310] FIGS. **37A**, **37B**, **37C**, **37D**, and **37E** are schematic cross-sectional views illustrating a method of manufacturing a light emitting diode stack for a display according to an exemplary embodiment.

[0311] Referring to FIG. **37A**, a first LED stack **1230** is grown on a first substrate **1210**. The first substrate **1210** may be, for example, a GaAs substrate. The first LED stack **1230** may be formed of AlGaInP-based semiconductor layers and includes an n-type semiconductor layer, an active layer, and a p-type semiconductor layer.

[0312] An insulation layer **1270** is formed on the first LED stack **1230**, and is patterned to form opening(s). For example, a SiO_2 layer is formed on the first LED stack **1230** and a photoresist is deposited onto the SiO_2 layer, followed by photolithography and development to form a photoresist pattern. Then, the SiO_2 layer is patterned through the photoresist pattern used as an etching mask, thereby forming the insulation layer **1270**.

[0313] Then, an ohmic contact layer **1250a** is formed in the opening(s) of the insulation layer **1270**. The ohmic contact layer **1250a** may be formed by a lift-off process or the like. After the ohmic contact layer **1250a** is formed, a

reflective layer **1250b** is formed to cover the ohmic contact layer **1250a** and the insulation layer **1270**. The reflective layer **1250b** may be formed by a lift-off process or the like. The reflective layer **1250b** may cover a portion of the ohmic contact layer **1250a** or the entirety thereof, as shown in FIG. **37A**. The ohmic contact layer **1250a** and the reflective layer **1250b** form a reflective electrode **1250**.

[0314] The reflective electrode **1250** forms ohmic contact with the p-type semiconductor layer of the first LED stack **1230**, and thus, will hereinafter be referred to as a first-p reflective electrode **1250**.

[0315] Referring to FIG. **37B**, a second LED stack **1330** is grown on a second substrate **1310**, and a second-p transparent electrode **1350** and a first color filter **1370** are formed on the second LED stack **1330**. The second LED stack **1330** may be formed of GaN-based semiconductor layers and include a GaInN well layer. The second substrate **1310** is a substrate on which GaN-based semiconductor layers may be grown thereon, and is different from the first substrate **1210**. The composition ratio of GaInN for the second LED stack **1330** may be determined such that the second LED stack **1330** emits green light. The second-p transparent electrode **1350** forms ohmic contact with the p-type semiconductor layer of the second LED stack **1330**.

[0316] Referring to FIG. **37C**, a third LED stack **1430** is grown on a third substrate **1410**, and a third-p transparent electrode **1450** and a second color filter **1470** are formed on the third LED stack **1430**. The third LED stack **1430** may be formed of GaN-based semiconductor layers and include a GaInN well layer. The third substrate **1410** is a substrate on which GaN-based semiconductor layers may be grown thereon, and is different from the first substrate **1210**. The composition ratio of GaInN for the third LED stack **1430** may be determined such that the third LED stack **1430** emits blue light. The third-p transparent electrode **1450** forms ohmic contact with the p-type semiconductor layer of the third LED stack **1430**.

[0317] The first color filter **1370** and the second color filter **1470** are substantially the same as those described with reference to FIG. **36**, and thus, repeated descriptions thereof will be omitted to avoid redundancy.

[0318] As such, the first LED stack **1230**, the second LED stack **1330** and the third LED stack **1430** may be grown on different substrates, and the formation sequence thereof is not limited to a particular sequence.

[0319] Referring to FIG. **37D**, the first LED stack **1230** is coupled to the support substrate **1510** via a first bonding layer **1530**. The first bonding layer **1530** may be previously formed on the support substrate **1510**, and the reflective electrode **1250** may be bonded to the first bonding layer **1530** to face the support substrate **1510**. The first substrate **1210** is removed from the first LED stack **1230** by chemical etching or the like. Accordingly, the upper surface of the n-type semiconductor layer of the first LED stack **1230** is exposed.

[0320] Then, an ohmic electrode **1290** is formed in the exposed region of the first LED stack **1230**. In order to reduce ohmic contact resistance of the ohmic electrode **1290**, the ohmic electrode **1290** may be subjected to heat treatment. The ohmic electrode **1290** may be formed in each pixel region so as to correspond to the pixel regions.

[0321] Referring to FIG. **37E**, the second LED stack **1330** is coupled to the first LED stack **1230**, on which the ohmic electrode **1290** is formed, via a second bonding layer **1550**.

The first color filter **1370** is bonded to the second bonding layer **1550** to face the first LED stack **1230**. The second bonding layer **1550** may be previously formed on the first LED stack **1230** so that the first color filter **1370** may face and be bonded to the second bonding layer **1550**. The second substrate **31** may be separated from the second LED stack **1330** by a laser lift-off or chemical lift-off process.

[0322] Then, referring to FIG. **36** and FIG. **37C**, the third LED stack **1430** is coupled to the second LED stack **1330** via a third bonding layer **1570**. The second color filter **1470** is bonded to the third bonding layer **1570** to face the second LED stack **1330**. The third bonding layer **1570** may be previously disposed on the second LED stack **1330** so that the second color filter **1470** may face and be bonded to the third bonding layer **1570**. The third substrate **1410** may be separated from the third LED stack **1430** by a laser lift-off or chemical lift-off process. As such a light emitting diode stack for a display may be formed as shown in FIG. **36**, which has the n-type semiconductor layer of the third LED stack **1430** exposed to the outside.

[0323] A display apparatus according to an exemplary embodiment may be provided by patterning the stack of the first to third LED stacks **1230**, **1330**, and **1430** on the support substrate **1510** in pixel units, followed by connecting the first to third LED stacks to one another through interconnections. Hereinafter, a display apparatus according to exemplary embodiments will be described.

[0324] FIG. **38** is a schematic circuit diagram of a display apparatus according to an exemplary embodiment, and FIG. **39** is a schematic plan view of the display apparatus according to an exemplary embodiment.

[0325] Referring to FIG. **38** and FIG. **39**, a display apparatus according to an exemplary embodiment may be operated in a passive matrix manner.

[0326] For example, since the light emitting diode stack for a display of FIG. **36** includes the first to third LED stacks **1230**, **1330**, and **1430** stacked in the vertical direction, one pixel may include three light emitting diodes R, G, and B. A first light emitting diode R may correspond to the first LED stack **1230**, a second light emitting diode G may correspond to the second LED stack **1330**, and a third light emitting diode B may correspond to the third LED stack **1430**.

[0327] In FIGS. **36** and **39**, one pixel includes the first to third light emitting diodes R, G, and B, each of which corresponds to a subpixel. Anodes of the first to third light emitting diodes R, G, and B are connected to a common line, for example, a data line, and cathodes thereof are connected to different lines, for example, scan lines. More particularly, in a first pixel, the anodes of the first to third light emitting diodes R, G, and B are commonly connected to a data line Vdata1 and the cathodes thereof are connected to scan lines Vscan1-1, Vscan1-2, and Vscan1-3, respectively. As such, the light emitting diodes R, G, and B in each pixel can be driven independently.

[0328] In addition, each of the light emitting diodes R, G, and B may be driven by a pulse width modulation or by changing the magnitude of electric current, thereby controlling the brightness of each subpixel.

[0329] Referring to FIG. **39**, a plurality of pixels is formed by patterning the light emitting diode stack **1000** of FIG. **36**, and each of the pixels is connected to the reflective electrodes **1250** and interconnection lines **1710**, **1730**, and **1750**. As shown in FIG. **38**, the reflective electrode **1250** may be

used as the data line Vdata and the interconnection lines **1710**, **1730**, and **1750** may be formed as the scan lines.

[0330] The pixels may be arranged in a matrix form, in which the anodes of the light emitting diodes R, G, and B of each pixel are commonly connected to the reflective electrode **1250**, and the cathodes thereof are connected to the interconnection lines **1710**, **1730**, and **1750** separated from one another. Here, the interconnection lines **1710**, **1730**, and **1750** may be used as the scan lines Vscan.

[0331] FIG. **40** is an enlarged plan view of one pixel of the display apparatus of FIG. **39**, FIG. **41** is a schematic cross-sectional view taken along line A-A of FIG. **40**, and FIG. **42** is a schematic cross-sectional view taken along line B-B of FIG. **40**.

[0332] Referring to FIG. **39**, FIG. **40**, FIG. **41**, and FIG. **42**, in each pixel, a portion of the reflective electrode **1250**, the ohmic electrode **1290** formed on the upper surface of the first LED stack **1230** (see FIG. **43H**), a portion of the second-p transparent electrode **1350** (see also FIG. **43H**), a portion of the upper surface of the second LED stack **1330** (see FIG. **43J**), a portion of the third-p transparent electrode **1450** (see FIG. **43H**), and the upper surface of the third LED stack **1430** are exposed to the outside.

[0333] The third LED stack **1430** may have a roughened surface **1430a** on the upper surface thereof. The roughened surface **1430a** may be formed over the entirety of the upper surface of the third LED stack **1430** or may be formed in some regions thereof, as shown in FIG. **41**.

[0334] A lower insulation layer **1610** may cover a side surface of each pixel. The lower insulation layer **1610** may be formed of a light transmissive material, such as SiO₂. In this case, the lower insulation layer **1610** may cover the entire upper surface of the third LED stack **1430**. Alternatively, the lower insulation layer **1610** may include a distributed Bragg reflector to reflect light traveling towards the side surfaces of the first to third LED stacks **1230**, **1330**, and **1430**. In this case, the lower insulation layer **1610** partially exposes the upper surface of the third LED stack **1430**.

[0335] The lower insulation layer **1610** may include an opening **1610a** which exposes the upper surface of the third LED stack **1430**, an opening **1610b** which exposes the upper surface of the second LED stack **1330**, an opening **1610c** (see FIG. **43H**) which exposes the ohmic electrode **1290** of the first LED stack **1230**, an opening **1610d** which exposes the third-p transparent electrode **1450**, an opening **1610e** which exposes the second-p transparent electrode **1350**, and openings **1610f** which expose the first-p reflective electrode **1250**.

[0336] The interconnection lines **1710** and **1750** may be formed near the first to third LED stacks **1230**, **1330**, and **1430** on the support substrate **1510**, and may be disposed on the lower insulation layer **1610** to be insulated from the first-p reflective electrode **1250**. A connecting portion **1770a** connects the third-p transparent electrode **1450** to the reflective electrode **1250**, and a connecting portion **1770b** connects the second-p transparent electrode **1350** to the reflective electrode **1250**, such that the anodes of the first LED stack **1230**, the second LED stack **1330**, and the third LED stack **1430** are commonly connected to the reflective electrode **1250**.

[0337] A connecting portion **1710a** connects the upper surface of the third LED stack **1430** to the interconnection

line 1710, and a connecting portion 1750a connects the ohmic electrode 1290 on the first LED stack 1230 to the interconnection line 1750.

[0338] An upper insulation layer 1810 may be disposed on the interconnection lines 1710 and 1730 and the lower insulation layer 1610 to cover the upper surface of the third LED stack 1430. The upper insulation layer 1810 may have an opening 1810a which partially exposes the upper surface of the second LED stack 1330.

[0339] The interconnection line 1730 may be disposed on the upper insulation layer 1810, and the connecting portion 1730a may connect the upper surface of the second LED stack 1330 to the interconnection line 1730. The connecting portion 1730a may pass through an upper portion of the interconnection line 1750, and is insulated from the interconnection line 1750 by the upper insulation layer 1810.

[0340] Although the electrodes of each pixel according to the illustrated exemplary embodiment are described as being connected to the data line and the scan lines, various implementations are possible. In addition, although the interconnection lines 1710 and 1750 are described as being formed on the lower insulation layer 1610, and the interconnection line 1730 formed on the upper insulation layer 1810, the inventive concepts are not limited thereto. For example, each of the interconnection lines 1710, 1730, and 1750 may be formed on the lower insulation layer 1610, and covered by the upper insulation layer 1810, which may have openings expose the interconnection line 1730. In this structure, the connecting portion 1730a may connect the upper surface of the second LED stack 1330 to the interconnection line 1730 through the openings of the upper insulation layer 1810.

[0341] Alternatively, the interconnection lines 1710, 1730, and 1750 may be formed inside the support substrate 1510, and the connecting portions 1710a, 1730a, and 1750a on the lower insulation layer 1610 may connect the ohmic electrode 1290, the upper surface of the second LED stack 1330, and the upper surface of the third LED stack 1430 to the interconnection lines 1710, 1730, and 1750.

[0342] FIG. 43A to FIG. 43K are schematic plan views illustrating a method of manufacturing a display apparatus including the pixel of FIG. 40 according to an exemplary embodiment.

[0343] First, the light emitting diode stack 1000 described in FIG. 36 is prepared.

[0344] Then, referring to FIG. 43A, a roughened surface 1430a may be formed on the upper surface of the third LED stack 1430. The roughened surface 1430a may be formed on the upper surface of the third LED stack 1430 so as to correspond to each pixel region. The roughened surface 1430a may be formed by chemical etching, for example, photo-enhanced to chemical etching (PEC) or the like.

[0345] The roughened surface 1430a may be partially formed in each pixel region by taking into account a region of the third LED stack 1430 to be etched in the subsequent process, without being limited thereto. Alternatively, the roughened surface 1430a may be formed over the entire upper surface of the third LED stack 1430.

[0346] Referring to FIG. 43B, a surrounding region of the third LED stack 1430 in each pixel is removed by etching to expose the third-p transparent electrode 1450. As shown in FIG. 43B, the third LED stack 1430 may be remained to

have a rectangular shape or a square shape. The third LED stack 1430 may have a plurality of depressions along edges thereof.

[0347] Referring to FIG. 43C, the upper surface of the second LED stack 1330 is exposed by removing the exposed third-p transparent electrode 1450 in areas other than one depression of the third LED stack 1430. Accordingly, the upper surface of the second LED stack 1330 is exposed around the third LED stack 1430 and in other depressions excluding the depression in which the third-p transparent electrode 1450 partially remains.

[0348] Referring to FIG. 43D, the second-p transparent electrode 1350 is exposed by removing the exposed second LED stack 1330 in areas other than another depression of the third LED stack 1430.

[0349] Referring to FIG. 43E, the ohmic electrode 1290 is exposed together with the upper surface of the first LED stack 1230 by removing the exposed second-p transparent electrode 1350 in areas other than still another depression of the third LED stack 1430. In this case, the ohmic electrode 1290 may be exposed in one depression. Accordingly, the upper surface of the first LED stack 1230 is exposed around the third LED stack 1430, and an upper surface of the ohmic electrode 1290 is exposed in at least one of the depressions formed in the third LED stack 1430.

[0350] Referring to FIG. 43F, the reflective electrode 1250 is exposed by removing an exposed portion of the first LED stack 1230 other than the ohmic electrode 1290 exposed in one depression. The reflective electrode 1250 is exposed around the third LED stack 1430.

[0351] Referring to FIG. 43G, linear interconnection lines are formed by patterning the reflective electrode 1250. Here, the support substrate 1510 may be exposed. The reflective electrode 1250 may connect pixels arranged in one row to each other among pixels arranged in a matrix (see FIG. 39).

[0352] Referring to FIG. 43H, a lower insulation layer 1610 (see FIG. 41 and FIG. 42) is formed to cover the pixels. The lower insulation layer 1610 covers the reflective electrode 1250 and side surfaces of the first to third LED stacks 1230, 1330, and 1430. In addition, the lower insulation layer 1610 may at least partially cover the upper surface of the third LED stack 1430. If the lower insulation layer 1610 is a transparent layer such as a SiO₂ layer, the lower insulation layer 1610 may cover the entire upper surface of the third LED stack 1430. Alternatively, when the lower insulation layer 1610 includes a distributed Bragg reflector, the lower insulation layer 1610 may at least partially expose the upper surface of the third LED stack 1430 such that light may be emitted to the outside.

[0353] The lower insulation layer 1610 may include an opening 1610a which exposes the third LED stack 1430, an opening 1610b which exposes the second LED stack 1330, an opening 1610c which exposes the ohmic electrode 1290, an opening 1610d which exposes the third-p transparent electrode 1450, an opening 1610e which exposes the second-p transparent electrode 1350, and an opening 1610f which exposes the reflective electrode 1250. One or more openings 1610f may be formed to expose the reflective electrode 1250.

[0354] Referring to FIG. 43I, interconnection lines 1710, 1750 and connecting portions 1710a, 1750a, 1770a, and 1770b are formed. These may be formed by a lift-off process or the like. The interconnection lines 1710 and 1750 are insulated from the reflective electrode 1250 by the lower

insulation layer **1610**. The connecting portion **1710a** electrically connects the third LED stack **1430** to the interconnection line **1710**, and the connecting portion **1750a** electrically connects the ohmic electrode **1290** to the interconnection line **1750** such that the first LED stack **1230** is electrically connected to the interconnection line **1750**. The connecting portion **1770a** electrically connects the third-p transparent electrode **1450** to the first-p reflective electrode **1250**, and the connecting portion **1770b** electrically connects the second-p transparent electrode **1350** to the first-p reflective electrode **1250**.

[0355] Referring to FIG. 43J, an upper insulation layer **1810** (see FIG. 41 and FIG. 42) covers the interconnection lines **1710** and **1750** and the connecting portions **1710a**, **1750a**, **1770a**, and **1770b**. The upper insulation layer **1810** may also cover the entire upper surface of the third LED stack **1430**. The upper insulation layer **1810** has an opening **1810a** which exposes the upper surface of the second LED stack **1330**. The upper insulation layer **1810** may be formed of, for example, silicon oxide or silicon nitride, and may include a distributed Bragg reflector. When the upper insulation layer **1810** includes the distributed Bragg reflector, the upper insulation layer **1810** may expose at least part of the upper surface of the third LED stack **1430** such that light may be emitted to the outside.

[0356] Referring to FIG. 43K, an interconnection line **1730** and a connecting portion **1730a** are formed. An interconnection line **1750** and a connecting portion **1750a** may be formed by a lift-off process or the like. The interconnection line **1730** is disposed on the upper insulation layer **1810**, and is insulated from the reflective electrode **1250** and the interconnection lines **1710** and **1750**. The connecting portion **1730a** electrically connects the second LED stack **1330** to the interconnection line **1730**. The connecting portion **1730a** may pass through an upper portion of the interconnection line **1750** and is insulated from the interconnection line **1750** by the upper insulation layer **1810**.

[0357] As such, a pixel region as shown in FIG. 40 may be formed. In addition, as shown in FIG. 39, a plurality of pixels may be formed on the support substrate **1510** and may be connected to one another by the first-p the reflective electrode **1250** and the interconnection lines **1710**, **1730**, and **1750** to be operated in a passive matrix manner.

[0358] Although the display apparatus above has been described as being configured to be operated in the passive matrix manner, the inventive concepts are not limited thereto. More particularly, a display apparatus according to some exemplary embodiments may be manufactured in various ways so as to be operated in the passive matrix manner using the light emitting diode stack shown in FIG. 36.

[0359] For example, although the interconnection line **1730** is illustrated as being formed on the upper insulation layer **1810**, the interconnection line **1730** may be formed together with the interconnection lines **1710** and **1750** on the lower insulation layer **1610**, and the connecting portion **1730a** may be formed on the upper insulation layer **1810** to connect the second LED stack **1330** to the interconnection line **1730**. Alternatively, the interconnection lines **1710**, **1730**, and **1750** may be disposed inside the support substrate **1510**.

[0360] FIG. 44 is a schematic circuit diagram of a display apparatus according to another exemplary embodiment. The

display apparatus according to the illustrated exemplary embodiment may be driven in an active matrix manner.

[0361] Referring to FIG. 44, the drive circuit according to an exemplary embodiment includes at least two transistors **Tr1**, **Tr2** and a capacitor. When a power source is connected to selection lines **Vrow1** to **Vrow3**, and voltage is applied to data lines **Vdata1** to **Vdata3**, the voltage is applied to the corresponding light emitting diode. In addition, the corresponding capacitor is charged according to the values of **Vdata1** to **Vdata3**. Since a turned-on state of a transistor **Tr2** can be maintained by the charged voltage of the capacitor, the voltage of the capacitor can be maintained and applied to the light emitting diodes **LED1** to **LED3** even when power supplied to **Vrow1** is cut off. In addition, electric current flowing in the light emitting diodes **LED1** to **LED3** can be changed depending upon the values of **Vdata1** to **Vdata3**. Electric current can be continuously supplied through **Vdd**, such that light may be emitted continuously.

[0362] The transistors **Tr1**, **Tr2** and the capacitor may be formed inside the support substrate **1510**. For example, thin film transistors formed on a silicon substrate may be used for active matrix driving.

[0363] The light emitting diodes **LED1** to **LED3** may correspond to the first to third LED stacks **1230**, **1330**, and **1430** stacked in one pixel, respectively. The anodes of the first to third LED stacks are connected to the transistor **Tr2** and the cathodes thereof are connected to the ground.

[0364] Although FIG. 44 shows the circuit for active matrix driving according to an exemplary embodiment, other various types of circuits may be used. In addition, although the anodes of the light emitting diodes **LED1** to **LED3** are described as being connected to different transistors **Tr2**, and the cathodes thereof are described as being connected to the ground, the inventive concepts are not limited thereto, and the anodes of the light emitting diodes may be connected to current supplies **Vdd** and the cathodes thereof may be connected to different transistors.

[0365] FIG. 45 is a schematic plan view of a pixel of a display apparatus according to another exemplary embodiment. The pixel described herein may be one of a plurality of pixels arranged on the support substrate **1511**.

[0366] Referring to FIG. 45, the pixels according to the illustrated exemplary embodiment are substantially similar to the pixels described with reference to FIG. 39 to FIG. 42, except that the support substrate **1511** is a thin film transistor panel including transistors and capacitors, and the reflective electrode is disposed in a lower region of the first LED stack.

[0367] The cathode of the third LED stack is connected to the support substrate **1511** through the connecting portion **1711a**. For example, as shown in FIG. 45, the cathode of the third LED stack may be connected to the ground through electrical connection to the support substrate **1511**. The cathodes of the second LED stack and the first LED stack may also be connected to the ground through electrical connection to the support substrate **1511** via the connecting portions **1731a** and **1751a**.

[0368] The reflective electrode is connected to the transistors **Tr2** (see FIG. 44) inside the support substrate **1511**. The third-p transparent electrode and the second-p transparent electrode are also connected to the transistors **Tr2** (see FIG. 44) inside the support substrate **1511** through the connecting portions **1771a** and **1731b**.

[0369] In this manner, the first to third LED stacks are connected to one another, thereby constituting a circuit for active matrix driving, as shown in FIG. 44.

[0370] Although FIG. 45 shows electrical connection of a pixel for active matrix driving according to an exemplary embodiment, the inventive concepts are not limited thereto, and the circuit for the display apparatus can be modified into various circuits for active matrix driving in various ways.

[0371] In addition, while the reflective electrode 1250, the second-p transparent electrode 1350, and the third-p transparent electrode 1450 of FIG. 36 are described as forming ohmic contact with the corresponding p-type semiconductor layer of each of the first LED stack 1230, the second LED stack 1330, and the third LED stack 1430, and the ohmic electrode 1290 forms ohmic contact with the n-type semiconductor layer of the first LED stack 1230, the n-type semiconductor layer of each of the second LED stack 1330 and the third LED stack 1430 is not provided with a separate ohmic contact layer. When the pixels have a small size of 200 μm or less, there is less difficulty in current spreading even without formation of a separate ohmic contact layer in the n-type semiconductor layer. However, according to some exemplary embodiments, a transparent electrode layer may be disposed on the n-type semiconductor layer of each of the LED stacks in order to secure current spreading.

[0372] In addition, although the first to third LED stacks 1230, 1330, and 1430 are coupled to each other via bonding layers 1530, 1550, and 1570, the inventive concepts are not limited thereto, and the first to third LED stacks 1230, 1330, and 1430 may be connected to one another in various sequences and using various structures.

[0373] According to exemplary embodiments, since it is possible to form a plurality of pixels at the wafer level using the light emitting diode stack 1000 for a display, individual mounting of light emitting diodes may be obviated. In addition, the light emitting diode stack according to the exemplary embodiments has the structure in which the first to third LED stacks 1230, 1330, and 1430 are stacked in the vertical direction, thereby securing an area for subpixels in a limited pixel area. Furthermore, the light emitting diode stack according to the exemplary embodiments allows light generated from the first LED stack 1230, the second LED stack 1330, and the third LED stack 1430 to be emitted outside therethrough, thereby reducing light loss.

[0374] FIG. 46 is a schematic cross-sectional view of a light emitting diode stack for a display according to an exemplary embodiment.

[0375] Referring to FIG. 46, the light emitting diode stack 2000 includes a support substrate 2510, a first LED stack 2230, a second LED stack 2330, a third LED stack 2430, a reflective electrode 2250, an ohmic electrode 2290, a second-p transparent electrode 2350, a third-p transparent electrode 2450, an insulation layer 2270, a first bonding layer 2530, a second bonding layer 2550, and a third bonding layer 2570. In addition, the first LED stack 2230 may include an ohmic contact portion 2230a for ohmic contact.

[0376] In general, light may be generated from the first LED stack by the light emitted from the second LED stack, and light may be generated from the second LED stack by the light emitted from the third LED stack. As such, a color filter may be interposed between the second LED stack and the first LED stack, and between the third LED stack and the second LED stack.

[0377] However, while the color filters may prevent interference of light, forming color filters increases manufacturing complexity. A display apparatus according to exemplary embodiments may suppress generation of secondary light between the LED stacks without arrangement of the color filters therebetween.

[0378] Accordingly, in some exemplary embodiments, interference of light between the LED stacks can be reduced by controlling the bandgap of each of the LED stacks, which will be described in more detail below.

[0379] The support substrate 2510 supports the semiconductor stacks 2230, 2330, and 2430. The support substrate 2510 may include a circuit on a surface thereof or therein, but the inventive concepts are not limited thereto. The support substrate 2510 may include, for example, a Si substrate, a Ge substrate, a sapphire substrate, a patterned sapphire substrate, a glass substrate, or a patterned glass substrate.

[0380] Each of the first LED stack 2230, the second LED stack 2330, and the third LED stack 2430 includes an n-type semiconductor layer, a p-type semiconductor layer, and an active layer interposed therebetween. The active layer may have a multi-quantum well structure.

[0381] Light L1 generated from the first LED stack 2230 has a longer wavelength than light L2 generated from the second LED stack 2330, which has a longer wavelength than light L3 generated from the third LED stack 2430.

[0382] The first LED stack 2230 may be an inorganic light emitting diode configured to emit red light, the second LED stack 2330 may be an inorganic light emitting diode configured to emit green light, and the third LED stack 2430 may be an inorganic light emitting diode configured to emit blue light. The first LED stack 2230 may include a GaInP-based well layer, and each of the second LED stack 2330 and the third LED stack 2430 may include a GaInN-based well layer.

[0383] Although the light emitting diode stack 2000 of FIG. 46 is illustrated as including three LED stacks 2230, 2330, and 2430, the inventive concepts are not limited to a particular number of LED stacks one over the other. For example, an LED stack for emitting yellow light may be further added between the first LED stack 2230 and the second LED stack 2330.

[0384] Both surfaces of each of the first to third LED stacks 2230, 2330, and 2430 are an n-type semiconductor layer and a p-type semiconductor layer, respectively. In FIG. 46, each of the first to third LED stacks 2230, 2330, and 2430 is described as having an n-type upper surface and a p-type lower surface. Since the third LED stack 2430 has an n-type upper surface, a roughened surface may be formed on the upper surface of the third LED stack 2430 through chemical etching or the like. However, the inventive concepts are not limited thereto, and the semiconductor types of the upper and lower surfaces of each of the LED stacks can be formed alternatively.

[0385] The first LED stack 2230 is disposed near the support substrate 2510, the second LED stack 2330 is disposed on the first LED stack 2230, and the third LED stack 2430 is disposed on the second LED stack. Since the first LED stack 2230 emits light having a longer wavelength than the second and third LED stacks 2330 and 2430, light L1 generated from the first LED stack 2230 can be emitted to the outside through the second and third LED stacks 2330 and 2430. In addition, since the second LED stack 2330

emits light having a longer wavelength than the third LED stack **2430**, light **L2** generated from the second LED stack **2330** can be emitted to the outside through the third LED stack **2430**. Light **L3** generated in the third LED stack **2430** is directly emitted outside from the third LED stack **2430**.

[0386] In an exemplary embodiment, the n-type semiconductor layer of the first LED stack **2230** may have a bandgap wider than the bandgap of the active layer of the first LED stack **2230**, and narrower than the bandgap of the active layer of the second LED stack **2330**. Accordingly, a portion of light generated from the second LED stack **2330** may be absorbed by the n-type semiconductor layer of the first LED stack **2230** before reaching the active layer of the first LED stack **2230**. As such, the intensity of light generated in the active layer of the first LED stack **2230** may be reduced by the light generated from the second LED stack **2330**.

[0387] In addition, the n-type semiconductor layer of the second LED stack **2330** has a bandgap wider than the bandgap of the active layer of each of the first LED stack **2230** and the second LED stack **2330**, and narrower than the bandgap of the active layer of the third LED stack **2430**. Accordingly, a portion of light generated from the third LED stack **2430** may be absorbed by the n-type semiconductor layer of the second LED stack **2330** before reaching the active layer of the second LED stack **2330**. As such, the intensity of light generated in the second LED stack **2330** or the first LED stack **2230** may be reduced by the light generated from the third LED stack **2430**.

[0388] The p-type semiconductor layer and the n-type semiconductor layer of the third LED stack **2430** has wider bandgaps than the active layers of the first LED stack **2230** and the second LED stack **2330**, thereby transmitting light generated from the first and second LED stacks **2230** and **2330** therethrough.

[0389] According to an exemplary embodiment, it is possible to reduce interference of light between the LED stacks **2230**, **2330**, and **2430** by adjusting the bandgaps of the n-type semiconductor layers or the p-type semiconductor layers of the first and second LED stacks **2230** and **2330**, which may obviate the need for other components, such as color filters. For example, the intensity of light generated from the second LED stack **2330** and emitted to the outside may be about 10 times or more than the intensity of the light generated from the first LED stack **2230** by the light generated from the second LED stack **2330**. Likewise, the intensity of light generated from the third LED stack **2430** and emitted to the outside may be about 10 times or more than the intensity of the light generated from the second LED stack **2330** caused by the light generated from the third LED stack **2430**. In this case, the intensity of the light generated from the third LED stack **2430** and emitted to the outside may be about 10 times or more than the intensity of the light generated from the first LED stack **2230** caused by the light generated from the third LED stack **2430**. Accordingly, it is possible to realize a display apparatus free from color contamination caused by interference of light.

[0390] The reflective electrode **2250** forms ohmic contact with the p-type semiconductor layer of the first LED stack **2230** and reflects light generated from the first LED stack **2230**. For example, the reflective electrode **2250** may include an ohmic contact layer **2250a** and a reflective layer **2250b**.

[0391] The ohmic contact layer **2250a** partially contacts the p-type semiconductor layer of the first LED stack **2230**.

In order to prevent absorption of light by the ohmic contact layer **2250a**, a region in which the ohmic contact layer **2250a** contacts the p-type semiconductor layer may not exceed about 50% of the total area of the p-type semiconductor layer. The reflective layer **2250b** covers the ohmic contact layer **2250a** and the insulation layer **2270**. As shown in FIG. **46**, the reflective layer **2250b** may cover substantially the entire ohmic contact layer **2250a**, without being limited thereto. Alternatively, the reflective layer **2250b** may cover a portion of the ohmic contact layer **2250a**.

[0392] Since the reflective layer **2250b** covers the insulation layer **2270**, an omnidirectional reflector can be formed by the stacked structure of the first LED stack **2230** having a relatively high index of refraction and the insulation layer **2270** having a relatively low index of refraction, and the reflective layer **2250b**. The reflective layer **2250b** may cover about 50% or more of the area of the first LED stack **2230** or most of the first LED stack **2230**, thereby improving luminous efficacy.

[0393] The ohmic contact layer **2250a** and the reflective layer **2250b** may be formed of metal layers, which may include Au. The reflective layer **2250b** may include metal having relatively high reflectance with respect to light generated from the first LED stack **2230**, for example, red light. On the other hand, the reflective layer **2250b** may include metal having relatively low reflectance with respect to light generated from the second LED stack **2330** and the third LED stack **2430**, for example, green light or blue light, to reduce interference of light having been generated from the second and third LED stacks **2330**, **2430** and traveling toward the support substrate **2510**.

[0394] The insulation layer **2270** is interposed between the support substrate **2510** and the first LED stack **2230**, and has openings that expose the first LED stack **2230**. The ohmic contact layer **2250a** is connected to the first LED stack **2230** in the openings of the insulation layer **2270**.

[0395] The ohmic electrode **2290** is disposed on the upper surface of the first LED stack **2230**. In order to reduce ohmic contact resistance of the ohmic electrode **2290**, the ohmic contact portion **2230a** may protrude from the upper surface of the first LED stack **2230**. The ohmic electrode **2290** may be disposed on the ohmic contact portion **2230a**.

[0396] The second-p transparent electrode **2350** forms ohmic contact with the p-type semiconductor layer of the second LED stack **2330**. The second-p transparent electrode **2350** may be formed of a metal layer or a conductive oxide layer that is transparent to red light and green light.

[0397] The third-p transparent electrode **2450** forms ohmic contact with the p-type semiconductor layer of the third LED stack **2430**. The third-p transparent electrode **2450** may be formed of a metal layer or a conductive oxide layer that is transparent to red light, green light, and blue light.

[0398] The reflective electrode **2250**, the second-p transparent electrode **2350**, and the third-p transparent electrode **2450** may assist in current spreading through ohmic contact with the p-type semiconductor layer of corresponding LED stacks.

[0399] The first bonding layer **2530** couples the first LED stack **2230** to the support substrate **2510**. As shown in FIG. **46**, the reflective electrode **2250** may adjoin the first bonding layer **2530**. The first bonding layer **2530** may be a light transmissive or opaque layer.

[0400] The second bonding layer 2550 couples the second LED stack 2330 to the first LED stack 2230. As shown in FIG. 46, the second bonding layer 2550 may adjoin the first LED stack 2230 and the second-p transparent electrode 2350. The ohmic electrode 2290 may be covered by the second bonding layer 2550. The second bonding layer 2550 transmits light generated from the first LED stack 2230. The second bonding layer 2550 may be formed of a light transmissive bonding material, for example, a light transmissive organic bonding agent or light transmissive spin-on-glass. Examples of the light transmissive organic bonding agent may include SU8, poly(methyl methacrylate) (PMMA), polyimide, Parylene, benzocyclobutene (BCB), and the like. In addition, the second LED stack 2330 may be bonded to the first LED stack 2230 by plasma bonding or the like.

[0401] The third bonding layer 2570 couples the third LED stack 2430 to the second LED stack 2330. As shown in FIG. 46, the third bonding layer 2570 may adjoin the second LED stack 2330 and the third-p transparent electrode 2450. However, the inventive concepts are not limited thereto. For example, a transparent conductive layer may be disposed on the second LED stack 2330. The third bonding layer 2570 transmits light generated from the first LED stack 2230 and the second LED stack 2330, and may be formed of, for example, light transmissive spin-on-glass.

[0402] Each of the second bonding layer 2550 and the third bonding layer 2570 may transmit light generated from the third LED stack 2430 and light generated from the second LED stack 2330.

[0403] FIG. 47A to FIG. 47E are schematic cross-sectional views illustrating a method of manufacturing a light emitting diode stack for a display according to an exemplary embodiment.

[0404] Referring to FIG. 47A, a first LED stack 2230 is grown on a first substrate 2210. The first substrate 2210 may be, for example, a GaAs substrate. The first LED stack 2230 is formed of AlGaInP-based semiconductor layers, and includes an n-type semiconductor layer, an active layer, and a p-type semiconductor layer. In some exemplary embodiments, the n-type semiconductor layer may have an energy bandgap capable absorbing light generated from the second LED stack 2330, and the p-type semiconductor layer may have an energy bandgap capable absorbing light generated from the second LED stack 2330.

[0405] An insulation layer 2270 is formed on the first LED stack 2230 and patterned to form opening(s) therein. For example, a SiO₂ layer is formed on the first LED stack 2230, and a photoresist is deposited onto the SiO₂ layer, followed by photolithography and development to form a photoresist pattern. Then, the SiO₂ layer is patterned through the photoresist pattern used as an etching mask, thereby forming the insulation layer 2270 having the opening(s).

[0406] Then, an ohmic contact layer 2250a is formed in the opening(s) of the insulation layer 2270. The ohmic contact layer 2250a may be formed by a lift-off process or the like. After the ohmic contact layer 2250a is formed, a reflective layer 2250b is formed to cover the ohmic contact layer 2250a and the insulation layer 2270. The reflective layer 2250b may be formed by a lift-off process or the like. The reflective layer 2250b may cover a portion of the ohmic contact layer 2250a or the entirety thereof. The ohmic contact layer 2250a and the reflective layer 2250b form a reflective electrode 2250.

[0407] The reflective electrode 2250 forms ohmic contact with the p-type semiconductor layer of the first LED stack 2230, and thus, will hereinafter be referred to as a first-p reflective electrode 2250.

[0408] Referring to FIG. 47B, a second LED stack 2330 is grown on a second substrate 2310, and a second-p transparent electrode 2350 is formed on the second LED stack 2330. The second LED stack 2330 may be formed of GaN-based semiconductor layers and may include a GaInN well layer. The second substrate 2310 is a substrate on which GaN-based semiconductor layers may be grown thereon, and is different from the first substrate 2210. The composition ratio of GaInN for the second LED stack 2330 may be determined such that the second LED stack 2330 emits green light. The second-p transparent electrode 2350 forms ohmic contact with the p-type semiconductor layer of the second LED stack 2330. The second LED stack 2330 may include an n-type semiconductor layer, an active layer, and a p-type semiconductor layer. In some exemplary embodiments, the n-type semiconductor layer of the second LED stack 2330 may have an energy bandgap capable of absorbing light generated from the third LED stack 2430, and the p-type semiconductor layer of the second LED stack 2330 may have an energy bandgap capable of absorbing light generated from the third LED stack 2430.

[0409] Referring to FIG. 47C, a third LED stack 2430 is grown on a third substrate 2410, and a third-p transparent electrode 2450 is formed on the third LED stack 2430. The third LED stack 2430 may be formed of GaN-based semiconductor layers and may include a GaInN well layer. The third substrate 2410 is a substrate on which GaN-based semiconductor layers may be grown thereon, and is different from the first substrate 2210. The composition ratio of GaInN for the third LED stack 2430 may be determined such that the third LED stack 2430 emits blue light. The third-p transparent electrode 2450 forms ohmic contact with the p-type semiconductor layer of the third LED stack 2430.

[0410] As such, the first LED stack 2230, the second LED stack 2330, and the third LED stack 2430 are grown on different substrates, and the formation sequence thereof is not limited to a particular sequence.

[0411] Referring to FIG. 47D, the first LED stack 2230 is coupled to the support substrate 2510 via a first bonding layer 2530. The first bonding layer 2530 may be previously formed on the support substrate 2510 and the reflective electrode 2250 may be bonded to the first bonding layer 2530 to face the support substrate 2510. The first substrate 2210 is removed from the first LED stack 2230 by chemical etching or the like. Accordingly, the upper surface of the n-type semiconductor layer of the first LED stack 2230 is exposed.

[0412] Then, an ohmic electrode 2290 is formed in the exposed region of the first LED stack 2230. In order to reduce ohmic contact resistance of the ohmic electrode 2290, the ohmic electrode 2290 may be subjected to heat treatment. The ohmic electrode 2290 may be formed in each pixel region so as to correspond to the pixel regions.

[0413] Referring to FIG. 47E, the second LED stack 2330 is coupled to the first LED stack 2230, on which the ohmic electrode 2290 is formed, via a second bonding layer 2550. The second-p transparent electrode 2350 is bonded to the second bonding layer 2550 to face the first LED stack 2230. The second bonding layer 2550 may be previously formed on the first LED stack 2230 such that the second-p trans-

parent electrode **2350** may face and be bonded to the second bonding layer **2550**. The second substrate **2310** may be separated from the second LED stack **2330** by a laser lift-off or chemical lift-off process.

[0414] Then, referring to FIG. **46** and FIG. **47C**, the third LED stack **2430** is coupled to the second LED stack **2330** via a third bonding layer **2570**. The third-p transparent electrode **2450** is bonded to the third bonding layer **2570** to face the second LED stack **2330**. The third bonding layer **2570** may be previously formed on the second LED stack **2330** such that the third-p transparent electrode **2450** may face and be bonded to the third bonding layer **2570**. The third substrate **2410** may be separated from the third LED stack **2430** by a laser lift-off or chemical lift-off process. As such, the light emitting diode stack for a display as shown in FIG. **46** may be formed, which has the n-type semiconductor layer of the third LED stack **2430** exposed to the outside.

[0415] A display apparatus may be formed by patterning the stack of the first to third LED stacks **2230**, **2330**, and **2430** disposed on the support substrate **2510** in pixel units, followed by connecting the first to third LED stacks **2230**, **2330**, and **2430** to one another through interconnections. However, the inventive concepts are not limited thereto. For example, a display apparatus may be manufactured by dividing the stack of the first to third LED stacks **2230**, **2330**, and **2430** into individual units, and transferring the first to third LED stacks **2230**, **2330**, and **2430** to other support substrates, such as a printed circuit board.

[0416] FIG. **48** is a schematic circuit diagram of a display apparatus according to an exemplary embodiment. FIG. **49** is a schematic plan view of the display apparatus according to an exemplary embodiment.

[0417] Referring to FIG. **48** and FIG. **49**, the display apparatus according to an exemplary embodiment may be implemented to be driven in a passive matrix manner.

[0418] The light emitting diode stack for a display shown in FIG. **46** has the structure including the first to third LED stacks **2230**, **2330**, and **2430** stacked in the vertical direction. Since one pixel includes three light emitting diodes R, G, and B, a first light emitting diode R may correspond to the first LED stack **2230**, a second light emitting diode G may correspond to the second LED stack **2330**, and a third light emitting diode B may correspond to the third LED stack **2430**.

[0419] Referring to FIGS. **48** and **49**, one pixel includes the first to third light emitting diodes R, G, and B, each of which may correspond to a subpixel. Anodes of the first to third light emitting diodes R, G, and B are connected to a common line, for example, a data line, and cathodes thereof are connected to different lines, for example, scan lines. For example, in a first pixel, the anodes of the first to third light emitting diodes R, G, and B are commonly connected to a data line V_{data1}, and the cathodes thereof are connected to scan lines V_{scan1-1}, V_{scan1-2}, and V_{scan1-3}, respectively. As such, the light emitting diodes R, G, and B in each pixel can be driven independently.

[0420] In addition, each of the light emitting diodes R, G, and B may be driven by a pulse width modulation or by changing the magnitude of electric current to control the brightness of each subpixel.

[0421] Referring to FIG. **49**, a plurality of pixels is formed by patterning the stack of FIG. **46**, and each of the pixels is connected to the reflective electrodes **2250** and interconnec-

tion lines **2710**, **2730**, and **2750**. As shown in FIG. **48**, the reflective electrode **2250** may be used as the data line V_{data} and the interconnection lines **2710**, **2730**, and **2750** may be formed as the scan lines.

[0422] The pixels may be arranged in a matrix form, in which the anodes of the light emitting diodes R, G, and B of each pixel are commonly connected to the reflective electrode **2250**, and the cathodes thereof are connected to the interconnection lines **2710**, **2730**, and **2750** separated from one another. Here, the interconnection lines **2710**, **2730**, and **2750** may be used as the scan lines V_{scan}.

[0423] FIG. **50** is an enlarged plan view of one pixel of the display apparatus of FIG. **49**. FIG. **51** is a schematic cross-sectional view taken along line A-A of FIG. **50**, and FIG. **52** is a schematic cross-sectional view taken along line B-B of FIG. **50**.

[0424] Referring to FIGS. **49** to **52**, in each pixel, a portion of the reflective electrode **2250**, the ohmic electrode **2290** formed on the upper surface of the first LED stack **2230** (see FIG. **53H**), a portion of the second-p transparent electrode **2350** (see FIG. **53H**), a portion of the upper surface of the second LED stack **2330** (see FIG. **53J**), a portion of the third-p transparent electrode **2450** (see FIG. **53H**), and the upper surface of the third LED stack **2430** are exposed to the outside.

[0425] The third LED stack **2430** may have a roughened surface **2430a** on the upper surface thereof. The roughened surface **2430a** may be formed over the entirety of the upper surface of the third LED stack **2430** or may be formed in some regions thereof.

[0426] A lower insulation layer **2610** may cover a side surface of each pixel. The lower insulation layer **2610** may be formed of a light transmissive material, such as SiO₂. In this case, the lower insulation layer **2610** may cover substantially the entire upper surface of the third LED stack **2430**. Alternatively, the lower insulation layer **2610** may include a distributed Bragg reflector to reflect light traveling towards the side surfaces of the first to third LED stacks **2230**, **2330**, and **2430**. In this case, the lower insulation layer **2610** may partially expose the upper surface of the third LED stack **2430**. Still alternatively, the lower insulation layer **2610** may be a black-based insulation layer that absorbs light. Furthermore, an electrically floating metallic reflective layer may be further formed on the lower insulation layer **2610** to reflect light emitted through the side surfaces of the first to third LED stacks **2230**, **2330**, and **2430**.

[0427] The lower insulation layer **2610** may include an opening **2610a** which exposes the upper surface of the third LED stack **2430**, an opening **2610b** which exposes the upper surface of the second LED stack **2330**, an opening **2610c** (see FIG. **53H**) which exposes the ohmic electrode **2290** of the first LED stack **2230**, an opening **2610d** which exposes the third-p transparent electrode **2450**, an opening **2610e** which exposes the second-p transparent electrode **2350**, and openings **2610f** which expose the first-p reflective electrode **2250**.

[0428] The interconnection lines **2710** and **2750** may be formed near the first to third LED stacks **2230**, **2330**, and **2430** on the support substrate **2510**, and may be disposed on the lower insulation layer **2610** to be insulated from the first-p reflective electrode **2250**. A connecting portion **2770a** connects the third-p transparent electrode **2450** to the reflective electrode **2250**, and a connecting portion **2770b** con-

nects the second-p transparent electrode **2350** to the reflective electrode **2250**, such that the anodes of the first LED stack **2230**, the second LED stack **2330**, and the third LED stack **2430** are commonly connected to the reflective electrode **2250**.

[0429] A connecting portion **2710a** connects the upper surface of the third LED stack **2430** to the interconnection line **2710**, and a connecting portion **2750a** connects the ohmic electrode **2290** on the first LED stack **2230** to the interconnection line **2750**.

[0430] An upper insulation layer **2810** may be disposed on the interconnection lines **2710** and **2730** and the lower insulation layer **2610** to cover the upper surface of the third LED stack **2430**. The upper insulation layer **2810** may have an opening **2810a** which partially exposes the upper surface of the second LED stack **2330**.

[0431] The interconnection line **2730** may be disposed on the upper insulation layer **2810**, and the connecting portion **2730a** may connect the upper surface of the second LED stack **2330** to the interconnection line **2730**. The connecting portion **2730a** may pass through an upper portion of the interconnection line **2750** and is insulated from the interconnection line **2750** by the upper insulation layer **2810**.

[0432] Although the electrodes of each pixel are described as being connected to the data line and the scan lines, the inventive concepts are not limited thereto. Further, while the interconnection lines **2710** and **2750** are described as being formed on the lower insulation layer **2610** and the interconnection line **2730** is described as being formed on the upper insulation layer **2810**, the inventive concepts are not limited thereto. For example, all of the interconnection lines **2710**, **2730**, and **2750** may be formed on the lower insulation layer **2610**, and may be covered by the upper insulation layer **2810**, which may have openings that expose the interconnection line **2730**. In this manner, the connecting portion **2730a** may connect the upper surface of the second LED stack **2330** to the interconnection line **2730** through the openings of the upper insulation layer **2810**.

[0433] Alternatively, the interconnection lines **2710**, **2730**, and **2750** may be formed inside the support substrate **2510**, and the connecting portions **2710a**, **2730a**, and **2750a** on the lower insulation layer **2610** may connect the ohmic electrode **2290**, the upper surface of the first LED stack **2230**, and the upper surface of the third LED stack **2430** to the interconnection lines **2710**, **2730**, and **2750**.

[0434] According to an exemplary embodiment, light **L1** generated from the first LED stack **2230** is emitted to the outside through the second and third LED stacks **2330** and **2430**, and light **L2** generated from the second LED stack **2330** is emitted to the outside through the third LED stack **2430**. Furthermore, a portion of light **L3** generated from the third LED stack **2430** may enter the second LED stack **2330**, and a portion of light **L2** generated from the second LED stack **2330** may enter the first LED stack **2230**. Furthermore, a secondary light may be generated from the second LED stack **2330** by the light **L3**, and a secondary light may also be generated from the first LED stack **2230** by the light **L2**. However, such secondary light may have a low intensity.

[0435] FIG. 53A to FIG. 53K are schematic plan views illustrating a method of manufacturing a display apparatus according to an exemplary embodiment. Hereinafter, the following descriptions will be given with reference to the pixel of FIG. 50.

[0436] First, the light emitting diode stack **2000** described in FIG. 46 is prepared.

[0437] Referring to FIG. 53A, a roughened surface **2430a** may be formed on the upper surface of the third LED stack **2430**. The roughened surface **2430a** may be formed on the upper surface of the third LED stack **2430** to correspond to each pixel region. The roughened surface **2430a** may be formed by chemical etching, for example, photo-enhanced chemical etching (PEC) or the like.

[0438] The roughened surface **2430a** may be partially formed in each pixel region by taking into account a region of the third LED stack **2430** to be etched in the subsequent process, without being limited thereto. Alternatively, the roughened surface **2430a** may be formed over the entire upper surface of the third LED stack **2430**.

[0439] Referring to FIG. 53B, a surrounding region of the third LED stack **2430** in each pixel is removed by etching to expose the third-p transparent electrode **2450**. As shown in FIG. 53B, the third LED stack **2430** may be remained to have a rectangular shape or a square shape. The third LED stack **2430** may have a plurality of depressions formed along edges thereof.

[0440] Referring to FIG. 53C, the upper surface of the second LED stack **2330** is exposed by removing the exposed third-p transparent electrode **2450** in areas other than in one depression. Accordingly, the upper surface of the second LED stack **2330** is exposed around the third LED stack **2430** and in other depressions other than the depression where the third-p transparent electrode **2450** is partially remained.

[0441] Referring to FIG. 53D, the second-p transparent electrode **2350** is exposed by removing the exposed second LED stack **2330** exposed in areas other than one depression.

[0442] Referring to FIG. 53E, the ohmic electrode **2290** is exposed together with the upper surface of the first LED stack **2230** by removing the exposed second-p transparent electrode **2350** in areas other than in one depression. Here, the ohmic electrode **2290** may be exposed in one depression. Accordingly, the upper surface of the first LED stack **2230** is exposed around the third LED stack **2430**, and an upper surface of the ohmic electrode **2290** is exposed in at least one of the depressions formed in the third LED stack **2430**.

[0443] Referring to FIG. 53F, the reflective electrode **2250** is exposed by removing an exposed portion of the first LED stack **2230** in areas other than in one depression. As such, the reflective electrode **2250** is exposed around the third LED stack **2430**.

[0444] Referring to FIG. 53G, linear interconnection lines are formed by patterning the reflective electrode **2250**. Here, the support substrate **2510** may be exposed. The reflective electrode **2250** may connect pixels arranged in one row to each other among pixels arranged in a matrix (see FIG. 49).

[0445] Referring to FIG. 53H, a lower insulation layer **2610** (see FIG. 51 and FIG. 52) is formed to cover the pixels. The lower insulation layer **2610** covers the reflective electrode **2250** and side surfaces of the first to third LED stacks **2230**, **2330**, and **2430**. In addition, the lower insulation layer **2610** may partially cover the upper surface of the third LED stack **2430**. If the lower insulation layer **2610** is a transparent layer such as a SiO₂ layer, the lower insulation layer **2610** may cover substantially the entire upper surface of the third LED stack **2430**. Alternatively, the lower insulation layer **2610** may include a distributed Bragg reflector. In this case,

the lower insulation layer 2610 may partially expose the upper surface of the third LED stack 2430 to allow light to be emitted to the outside.

[0446] The lower insulation layer 2610 may include an opening 2610a which exposes the third LED stack 2430, an opening 2610b which exposes the second LED stack 2330, an opening 2610c which exposes the ohmic electrode 2290, an opening 2610d which exposes the third-p transparent electrode 2450, an opening 2610e which exposes the second-p transparent electrode 2350, and an opening 2610f which exposes the reflective electrode 2250. The opening 2610f that exposes the reflective electrode 2250 may be formed singularly or in plural.

[0447] Referring to FIG. 53I, interconnection lines 2710 and 2750, and connecting portions 2710a, 2750a, 2770a, and 2770b are formed by a lift-off process or the like. The interconnection lines 2710 and 2750 are insulated from the reflective electrode 2250 by the lower insulation layer 2610. The connecting portion 2710a electrically connects the third LED stack 2430 to the interconnection line 2710, and the connecting portion 2750a electrically connects the ohmic electrode 2290 to the interconnection line 2750 such that the first LED stack 2230 is electrically connected to the interconnection line 2750. The connecting portion 2770a electrically connects the third-p transparent electrode 2450 to the first-p reflective electrode 2250, and the connecting portion 2770b electrically connects the second-p transparent electrode 2350 to the first-p reflective electrode 2250.

[0448] Referring to FIG. 53J, an upper insulation layer 2810 (see FIG. 51 and FIG. 52) covers the interconnection lines 2710, 2750 and the connecting portions 2710a, 2750a, 2770a, and 2770b. The upper insulation layer 2810 may also cover substantially the entire upper surface of the third LED stack 2430. The upper insulation layer 2810 has an opening 2810a which exposes the upper surface of the second LED stack 2330. The upper insulation layer 2810 may be formed of, for example, silicon oxide or silicon nitride, and may include a distributed Bragg reflector. When the upper insulation layer 2810 includes the distributed Bragg reflector, the upper insulation layer 2810 may expose at least a part of the upper surface of the third LED stack 2430 to allow light to be emitted to the outside.

[0449] Referring to FIG. 53K, an interconnection line 2730 and a connecting portion 2730a are formed. An interconnection line 2750 and a connecting portion 2750a may be formed by a lift-off process or the like. The interconnection line 2730 is disposed on the upper insulation layer 2810, and is insulated from the reflective electrode 2250 and the interconnection lines 2710 and 2750. The connecting portion 2730a electrically connects the second LED stack 2330 to the interconnection line 2730. The connecting portion 2730a may pass through an upper portion of the interconnection line 2750, and is insulated from the interconnection line 2750 by the upper insulation layer 2810.

[0450] As such, a pixel region shown in FIG. 50 may be formed. In addition, as shown in FIG. 49, a plurality of pixels may be formed on the support substrate 2510 and may be connected to one another by the first-p reflective electrode 2250 and the interconnection lines 2710, 2730 and 2750, to be operated in a passive matrix manner.

[0451] Although the above describes a method of manufacturing a display apparatus that may be operated in the passive matrix manner, the inventive concepts are not limited thereto. More particularly, the display apparatus accord-

ing to exemplary embodiments may be manufactured in various ways so as to be operated in the passive matrix manner using the light emitting diode stack shown in FIG. 46.

[0452] For example, while the interconnection line 2730 is described as being formed on the upper insulation layer 2810, the interconnection line 2730 may be formed together with the interconnection lines 2710 and 2750 on the lower insulation layer 2610, and the connecting portion 2730a may be formed on the upper insulation layer 2810 to connect the second LED stack 2330 to the interconnection line 2730. Alternatively, the interconnection lines 2710, 2730, 2750 may be disposed inside the support substrate 2510.

[0453] FIG. 54 is a schematic circuit diagram of a display apparatus according to another exemplary embodiment. The circuit diagram of FIG. 54 relates to a display apparatus driven in an active matrix manner.

[0454] Referring to FIG. 54, the drive circuit according to an exemplary embodiment includes at least two transistors Tr1, Tr2 and a capacitor. When a power source is connected to selection lines Vrow1 to Vrow3 and voltage is applied to data lines Vdata1 to Vdata3, the voltage is applied to the corresponding light emitting diode. In addition, the corresponding capacitors are charged according to the values of Vdata1 to Vdata3. Since a turned-on state of the transistor Tr2 can be maintained by the charged voltage of the capacitor, the voltage of the capacitor can be maintained and applied to the light emitting diodes LED1 to LED3, even when power supplied to Vrow1 is cut off. In addition, electric current flowing in the light emitting diodes LED1 to LED3 can be changed depending upon the values of Vdata1 to Vdata3. Electric current can be continuously supplied through Vdd, and thus, light may be emitted continuously.

[0455] The transistors Tr1, Tr2 and the capacitor may be formed inside the support substrate 2510. For example, thin film transistors formed on a silicon substrate may be used for active matrix driving.

[0456] Here, the light emitting diodes LED1 to LED3 may correspond to the first to third LED stacks 2230, 2330, and 2430 stacked in one pixel, respectively. The anodes of the first to third LED stacks 2230, 2330, and 2430 are connected to the transistor Tr2 and the cathodes thereof are connected to the ground.

[0457] Although FIG. 54 shows the circuit for active matrix driving according to an exemplary embodiment, other types of circuits may be variously used. In addition, although the anodes of the light emitting diodes LED1 to LED3 are described as being connected to different transistors Tr2 and the cathodes thereof are described as being connected to the ground, the anodes of the light emitting diodes may be connected to current supplies Vdd and the cathodes thereof may be connected to different transistors in some exemplary embodiments.

[0458] FIG. 55 is a schematic plan view of a display apparatus according to another exemplary embodiment. Hereinafter, the following description will be given with reference to one pixel among a plurality of pixels arranged on the support substrate 2511.

[0459] Referring to FIG. 55, the pixel according to an exemplary embodiment are substantially similar to the pixel described with reference to FIG. 49 to FIG. 52, except that the support substrate 2511 is a thin film transistor panel

including transistors and capacitors and the reflective electrode **2250** is disposed in a lower region of the first LED stack **2230**.

[0460] The cathode of the third LED stack **2430** is connected to the support substrate **2511** through the connecting portion **2711a**. For example, as shown in FIG. **54**, the cathode of the third LED stack **2430** may be connected to the ground through electrical connection to the support substrate **2511**. The cathodes of the second LED stack **2330** and the first LED stack **2230** may also be connected to the ground through electrical connection to the support substrate **2511** via the connecting portions **2731a** and **2751a**.

[0461] The reflective electrode is connected to the transistors Tr2 (see FIG. **54**) inside the support substrate **2511**. The third-p transparent electrode and the second-p transparent electrode are also connected to the transistors Tr2 (see FIG. **54**) inside the support substrate **2511** through the connecting portions **2711b** and **2731b**.

[0462] In this manner, the first to third LED stacks are connected to one another, thereby forming a circuit for active matrix driving, as shown in FIG. **54**.

[0463] Although FIG. **55** shows a pixel having an electrical connection for active matrix driving according to an exemplary embodiment, the inventive concepts are not limited thereto, and the circuit for the display apparatus can be modified into various circuits for active matrix driving in various ways.

[0464] In addition, the reflective electrode **2250**, the second-p transparent electrode **2350**, and the third-p transparent electrode **2450** of FIG. **46** are described as forming ohmic contact with the p-type semiconductor layer of each of the first LED stack **2230**, the second LED stack **2330**, and the third LED stack **2430**, and the ohmic electrode **2290** is described as forming ohmic contact with the n-type semiconductor layer of the first LED stack **2230**, the n-type semiconductor layer of each of the second LED stack **2330**, and the third LED stack **2430** is not provided with a separate ohmic contact layer. Although there is less difficulty in current spreading even without formation of a separate ohmic contact layer in the n-type semiconductor layer when the pixels have a small size of 200 μm or less, however, a transparent electrode layer may be disposed on the n-type semiconductor layer of each of the LED stacks in order to secure current spreading according to some exemplary embodiments.

[0465] In addition, although FIG. **46** shows the coupling of the first to third LED stacks **2230**, **2330**, and **2430** to one another via a bonding layers, the inventive concepts are not limited thereto, and the first to third LED stacks **2230**, **2330**, and **2430** may be connected to one another in various sequences and using various structures.

[0466] According to exemplary embodiments, since it is possible to form a plurality of pixels at the wafer level using the light emitting diode stack **2000** for a display, the need for individual mounting of light emitting diodes may be obviated. In addition, the light emitting diode stack according to exemplary embodiments has the structure in which the first to third LED stacks **2230**, **2330**, and **2430** are stacked in the vertical direction, and thus, an area for subpixels may be secured in a limited pixel area. Furthermore, the light emitting diode stack according to the exemplary embodiments allows light generated from the first LED stack **2230**,

the second LED stack **2330**, and the third LED stack **2430** to be emitted outside therethrough, thereby reducing light loss.

[0467] FIG. **56** is a schematic plan view of a display apparatus according to an exemplary embodiment, and FIG. **57** is a schematic cross-sectional view of a light emitting diode pixel for a display according to an exemplary embodiment.

[0468] Referring to FIG. **56** and FIG. **57**, the display apparatus includes a circuit board **3510** and a plurality of pixels **3000**. Each of the pixels **3000** includes a substrate **3210** and first to third subpixels R, G, and B disposed on the substrate **3210**.

[0469] The circuit board **3510** may include a passive circuit or an active circuit. The passive circuit may include, for example, data lines and scan lines. The active circuit may include, for example, a transistor and a capacitor. The circuit board **3510** may have a circuit on a surface thereof or therein. The circuit board **3510** may include, for example, a glass substrate, a sapphire substrate, a Si substrate, or a Ge substrate.

[0470] The substrate **3210** supports first to third subpixels R, G, and B. The substrate **3210** is continuous over the plurality of pixels **3000** and electrically connects the subpixels R, G, and B to the circuit board **3510**. For example, the substrate **3210** may be a GaAs substrate.

[0471] The first subpixel R includes a first LED stack **3230**, the second subpixel G includes a second LED stack **3330**, and the third subpixel B includes a third LED stack **3430**. The first subpixel R is configured to allow the first LED stack **3230** to emit light, the second subpixel G is configured to allow the second LED stack **3330** to emit light, and the third subpixel B is configured to allow the third LED stack **3430** to emit light. The first to third LED stacks **3230**, **3330**, and **3430** may be driven independently.

[0472] The first LED stack **3230**, the second LED stack **3330**, and the third LED stack **3430** are stacked to overlap one another in the vertical direction. Here, as shown in FIG. **57**, the second LED stack **3330** may be disposed in a portion of the first LED stack **3230**. For example, the second LED stack **3330** may be disposed towards one side on the first LED stack **3230**. The third LED stack **3430** may be disposed in a portion of the second LED stack **3330**. For example, the third LED stack **3430** may be disposed towards one side on the second LED stack **3330**. Although FIG. **57** shows that the third LED stack **3430** is disposed towards right side, the inventive concepts are not limited thereto. Alternatively, the third LED stack **3430** may be disposed towards the left side of the second LED stack **3330**.

[0473] Light R generated from the first LED stack **3230** may be emitted through a region not covered by the second LED stack **3330**, and light G generated from the second LED stack **3330** may be emitted through a region not covered by the third LED stack **3430**. More particularly, light generated from the first LED stack **3230** may be emitted to the outside without passing through the second LED stack **3330** and the third LED stack **3430**, and light generated from the second LED stack **3330** may be emitted to the outside without passing through the third LED stack **3430**.

[0474] The region of the first LED stack **3230** through which the light R is emitted, the region of the second LED stack **3330** through which the light G is emitted, and the region of the third LED stack **3430** may have different areas,

and the intensity of light emitted from each of the LED stacks 3230, 3330, and 3430 may be adjusted by adjusting the areas thereof.

[0475] However, the inventive concepts are not limited thereto. Alternatively, light generated from the first LED stack 3230 may be emitted to the outside after passing through the second LED stack 3330 or after passing through the second LED stack 3330 and the third LED stack 3430, and light generated from the second LED stack 3330 may be emitted to the outside after passing through the third LED stack 3430.

[0476] Each of the first LED stack 3230, the second LED stack 3330, and the third LED stack 3430 may include a first conductivity type (for example, n-type) semiconductor layer, a second conductivity type (for example, p-type) semiconductor layer, and an active layer interposed therebetween. The active layer may have a multi-quantum well structure. The first to third LED stacks 3230, 3330, and 3430 may include different active layers to emit light having different wavelengths. For example, the first LED stack 3230 may be an inorganic light emitting diode configured to emit red light, the second LED stack 3330 may be an inorganic light emitting diode configured to emit green light, and the third LED stack 3430 may be an inorganic light emitting diode configured to emit blue light. To this end, the first LED stack 3230 may include an AlGaInP-based well layer, the second LED stack 3330 may include an AlGaInP or AlGaInN-based well layer, and the third LED stack 3430 may include an AlGaInN-based well layer. However, the inventive concepts are not limited thereto. The wavelengths of light generated from the first LED stack 3230, the second LED stack 3330, and the third LED stack 3430 may be varied. For example, the first LED stack 3230, the second LED stack 3330, and the third LED stack 3430 may emit green light, red light, and blue light, respectively, or may emit green light, blue light, and red light, respectively.

[0477] In addition, a distributed Bragg reflector may be interposed between the substrate 3210 and the first LED stack 3230 to prevent loss of light generated from the first LED stack 3230 through absorption by the substrate 3210. For example, a distributed Bragg reflector formed by alternately stacking AlAs and AlGaAs semiconductor layers one above another may be interposed therebetween.

[0478] FIG. 58 is a schematic circuit diagram of a display apparatus according to an exemplary embodiment.

[0479] Referring to FIG. 58, the display apparatus according to an exemplary embodiment may be driven in an active matrix manner. As such, the circuit board may include an active circuit.

[0480] For example, the drive circuit may include at least two transistors Tr1, Tr2 and a capacitor. When a power source is connected to selection lines Vrow1 to Vrow3 and voltage is applied to data lines Vdata1 to Vdata3, the voltage is applied to the corresponding light emitting diode. In addition, the corresponding capacitors are charged according to the values of Vdata1 to Vdata3. Since a turned-on state of the transistor Tr2 can be maintained by the charged voltage of the capacitor, the voltage of the capacitor can be maintained and applied to the light emitting diodes LED1 to LED3 even when power supplied to Vrow1 is cut off. In addition, electric current flowing in the light emitting diodes LED1 to LED3 can be changed depending upon the values

of Vdata1 to Vdata3. Electric current can be continuously supplied through Vdd, and thus, light may be emitted continuously.

[0481] The transistors Tr1, Tr2 and the capacitor may be formed inside the support substrate 3510. Here, the light emitting diodes LED1 to LED3 may correspond to the first to third LED stacks 3230, 3330, and 3430 stacked in one pixel, respectively. The anodes of the first to third LED stacks 3230, 3330, and 3430 are connected to the transistor Tr2 and the cathodes thereof are connected to the ground. The cathodes of the first to third LED stacks 3230, 3330, and 3430, for example, may be commonly connected to the ground.

[0482] Although FIG. 58 shows the circuit for active matrix driving according to an exemplary embodiment, other types of circuits may also be used. In addition, although the anodes of the light emitting diodes LED1 to LED3 are described as being connected to different transistors Tr2 and the cathodes thereof are described as being connected to the ground, the anodes of the light emitting diodes may be commonly connected and the cathodes thereof may be connected to different transistors in some exemplary embodiments.

[0483] Although the active circuit for active matrix driving is illustrated above, the inventive concepts are not limited thereto, and the pixels according to an exemplary embodiment may be driven in a passive matrix manner. As such, the circuit board 3510 may include data lines and scan lines arranged thereon, and each of the subpixels may be connected to the data line and the scan line. In an exemplary embodiment, the anodes of the first to third LED stacks 3230, 3330, and 3430 may be connected to different data lines and the cathodes thereof may be commonly connected to a scan line. In other exemplary embodiments, the anodes of the first to third LED stacks 3230, 3330, and 3430 may be connected to different scan lines and the cathodes thereof may be commonly connected to a data line.

[0484] In addition, each of the LED stacks 3230, 3330, and 3430 may be driven by a pulse width modulation or by changing the magnitude of electric current, thereby controlling the brightness of each subpixel. Furthermore, the brightness may be adjusted by adjusting the areas of the first to third LED stacks 3230, 3330, and 3430, and the areas of the regions of the LED stacks 3230, 3330, and 3430 through which light R, G, and B is emitted. For example, an LED stack emitting light having low visibility, for example, the first LED stack 3230, has a larger area than the second LED stack 3330 or the third LED stack 3430, and thus, can emit light with a higher intensity under the same current density. In addition, since the area of the second LED stack 3330 is larger than the area of the third LED stack 3430, the second LED stack 3330 can emit light with a higher intensity under the same current density than the third LED stack 3430. In this manner, light output can be adjusted based on the visibility of light emitted from the first to third LED stacks 3230, 3330, and 3430 by adjusting the areas of the first LED stack 3230, the second LED stack 3330, and the third LED stack 3430.

[0485] FIG. 59A and FIG. 59B are a top view and a bottom view of one pixel of a display apparatus according to an exemplary embodiment, and FIG. 60A, FIG. 60B, FIG. 60C, and FIG. 60D are schematic cross-sectional views taken along lines A-A, B-B, C-C, and D-D of FIG. 59A, respectively.

[0486] In the display apparatus, pixels are arranged on a circuit board 3510 (see FIG. 56) and each of the pixel includes a substrate 3210 and subpixels R, G, and B. The substrate 3210 may be continuous over the plurality of pixels. Hereinafter, a configuration of a pixel according to an exemplary embodiment will be described.

[0487] Referring to FIG. 59AA, FIG. 59B, FIG. 60A, FIG. 60B, FIG. 60C, and FIG. 60D, the pixel includes a substrate 3210, a distributed Bragg reflector 3220, an insulation layer 3250, through-hole vias 3270a, 3270b, 3270c, a first LED stack 3230, a second LED stack 3330, a third LED stack 3430, a first-1 ohmic electrode 3290a, a first-2 ohmic electrode 3290b, a second-1 ohmic electrode 3390, a second-2 ohmic electrode 3350, a third-1 ohmic electrode 3490, a third-2 ohmic electrode 3450, a first bonding layer 3530, a second bonding layer 3550, an upper insulation layer 3610, connectors 3710, 3720, 3730, a lower insulation layer 3750, and electrode pads 3770a, 3770b, 3770c, 3770d.

[0488] Each of subpixels R, G, and B includes the LED stacks 3230, 3330, and 3430 and ohmic electrodes. In addition, anodes of the first to third subpixels R, G, and B may be electrically connected to the electrode pads 3770a, 3770b, and 3770c, respectively, and cathodes thereof may be electrically connected to the electrode pad 3770d, thereby allowing the first to third subpixels R, G, and B to be driven independently.

[0489] The substrate 3210 supports the LED stacks 3230, 3330, and 3430. The substrate 3210 may be a growth substrate on which AlGaInP-based semiconductor layers may be grown thereon, for example, a GaAs substrate. In particular, the substrate 3210 may be a semiconductor substrate exhibiting n-type conductivity.

[0490] The first LED stack 3230 includes a first conductivity type semiconductor layer 3230a and a second conductivity type semiconductor layer 3230b, the second LED stack 3330 includes a first conductivity type semiconductor layer 3330a and a second conductivity type semiconductor layer 3330b, and the third LED stack 3430 includes a first conductivity type semiconductor layer 3430a and a second conductivity type semiconductor layer 3430b. An active layer may be interposed between the first conductivity type semiconductor layer 3230a, 3330a, or 3430a and the second conductivity type semiconductor layer 3230b, 3330b, or 3430b.

[0491] According to an exemplary embodiment, each of the first conductivity type semiconductor layers 3230a, 3330a, 3430a may be an n-type semiconductor layer, and each of the second conductivity type semiconductor layers 3230b, 3330b, 3430b may be a p-type semiconductor layer. A roughened surface may be formed on an upper surface of each of the first conductivity type semiconductor layers 3230a, 3330a, 3430a by surface texturing. However, the inventive concepts are not limited thereto and the first and second conductivity types can be changed vice versa.

[0492] The first LED stack 3230 is disposed near the support substrate 3510, the second LED stack 3330 is disposed on the first LED stack 3230, and the third LED stack 3430 is disposed on the second LED stack 3330. The second LED stack 3330 is disposed in some region on the first LED stack 3230, so that the first LED stack 3230 partially overlaps the second LED stack 3330. The third LED stack 3430 is disposed in some region on the second LED stack 3330, so that the second LED stack 3330 partially overlaps the third LED stack 3430. Accordingly, light gen-

erated from the first LED stack 3230 can be emitted to the outside without passing through the second and third LED stacks 3330 and 3430. In addition, light generated from the second LED stack 3330 can be emitted to the outside without passing through the third LED stack 3430.

[0493] Materials for the first LED stack 3230, the second LED stack 3330, and the third LED stack 3430 are substantially the same as those described with reference to FIG. 57, and thus, detailed descriptions thereof will be omitted to avoid redundancy.

[0494] The distributed Bragg reflector 3220 is interposed between the substrate 3210 and the first LED stack 3230. The distributed Bragg reflector 3220 may include a semiconductor layer grown on the substrate 3210. For example, the distributed Bragg reflector 3220 may be formed by alternately stacking AlAs layers and AlGaAs layers. The distributed Bragg reflector 3220 may include a semiconductor layer that electrically connects the substrate 3210 to the first conductivity type semiconductor layer 3230a of the first LED stack 3230.

[0495] Through-hole vias 3270a, 3270b, 3270c are formed through the substrate 3210. The through-hole vias 3270a, 3270b, 3270c may be formed to pass through the first LED stack 3230. The through-hole vias 3270a, 3270b, 3270c may be formed of conductive pastes or by plating.

[0496] The insulation layer 3250 is disposed between the through-hole vias 3270a, 3270b, and 3270c and an inner wall of a through-hole formed through the substrate 3210 and the first LED stack 3230 to prevent short circuit between the first LED stack 3230 and the substrate 3210.

[0497] The first-1 ohmic electrode 3290a forms ohmic contact with the first conductivity type semiconductor layer 3230a of the first LED stack 3230. The first-1 ohmic electrode 3290a may be formed of, for example, Au—Te or Au—Ge alloys.

[0498] In order to form the first-1 ohmic electrode 3290a, the second conductivity type semiconductor layer 3230b and the active layer may be partially removed to expose the first conductivity type semiconductor layer 3230a. The first-1 ohmic electrode 3290a may be disposed apart from the region where the second LED stack 3330 is disposed. Furthermore, the first-1 ohmic electrode 3290 may include a pad region and an extension, and the connector 3710 may be connected to the pad region of the first-1 ohmic electrode 3290, as shown in FIG. 59A.

[0499] The first-2 ohmic electrode 3290b forms ohmic contact with the second conductivity type semiconductor layer 3230b of the first LED stack 3230. As shown in FIG. 59A, the first-2 ohmic electrode 3290b may be formed to partially surround the first-1 ohmic electrode 3290a in order to assist in current spreading. The first-2 ohmic electrode 3290b may not include the extension. The first-2 ohmic electrode 3290b may be formed of, for example, Au—Zn or Au—Be alloys. Furthermore, the first-2 ohmic electrode 3290b may have a single layer or multiple layers structure.

[0500] The first-2 ohmic electrode 3290b may be connected to the through-hole via 3270a such that the through-hole via 3270a can be electrically connected to the second conductivity type semiconductor layer 3230b.

[0501] The second-1 ohmic electrode 3390 forms ohmic contact with the first conductivity type semiconductor layer 3330a of the second LED stack 3330. The second-1 ohmic electrode 3390 may also include a pad region and an extension. As shown in FIG. 59A, the connector 3710 may

electrically connect the second-1 ohmic electrode **3390** to the first-1 ohmic electrode **3290a**. The second-1 ohmic electrode **3390** may be disposed apart from the region where the third LED stack **3430** is disposed.

[0502] The second-2 ohmic electrode **3350** forms ohmic contact with the second conductivity type semiconductor layer **3330b** of the second LED stack **3330**. The second-2 ohmic electrode **3350** may include a reflective layer **3350a** and a barrier layer **3350b**. The reflective layer **3350a** reflects light generated from the second LED stack **3330** to improve luminous efficacy of the second LED stack **3330**. The barrier layer **3350b** may act as a connection pad, which provides the reflective layer **3350a**, and is connected to the connector **3720**. Although the second-2 ohmic electrode **3350** is described as including a metal layer in this exemplary embodiment, the inventive concepts are not limited thereto. For example, the second-2 ohmic electrode **3350** may be formed of a transparent conductive oxide, such as a conductive oxide semiconductor layer.

[0503] The third-1 ohmic electrode **3490** forms ohmic contact with the first conductivity type semiconductor layer **3430a** of the third LED stack **3430**. The third-1 ohmic electrode **3490** may also include a pad region and an extension, and the connector **3710** may connect the third-1 ohmic electrode **3490** to the first-1 ohmic electrode **3290a**, as shown in FIG. 59A.

[0504] The third-2 ohmic electrode **3450** may form ohmic contact with the second conductivity type semiconductor layer **3430b** of the third LED stack **3430**. The third-2 ohmic electrode **3450** may include a reflective layer **3450a** and a barrier layer **3450b**. The reflective layer **3450a** reflects light generated from the third LED stack **3430** to improve luminous efficacy of the third LED stack **3430**. The barrier layer **3450b** may act as a connection pad, which provides the reflective layer **3450a**, and is connected to the connector **3730**. Although the third-2 ohmic electrode **3450** is described as including a metal layer, the inventive concepts are not limited thereto. Alternatively, the third-2 ohmic electrode **3450** may be formed of a transparent conductive oxide, such as a conductive oxide semiconductor layer.

[0505] The first-2 ohmic electrode **3290b**, the second-2 ohmic electrode **3350**, and the third-2 ohmic electrode **3450** may form ohmic contact with the p-type semiconductor layers of the corresponding LED stacks to assist in current spreading, and the first-1 ohmic electrode **3290a**, the second-1 ohmic electrode **3390**, and the third-1 ohmic electrode **3490** may form ohmic contact with the n-type semiconductor layers of the corresponding LED stacks to assist in current spreading.

[0506] The first bonding layer **3530** couples the second LED stack **3330** to the first LED stack **3230**. As shown in the drawings, the second-2 ohmic electrode **3350** may adjoin the first bonding layer **3530**. The first bonding layer **3530** may be a light transmissive layer or an opaque layer. The first bonding layer **3530** may be formed of an organic material or an inorganic material. Examples of the organic material may include SU8, poly(methyl methacrylate) (PMMA), polyimide, Parylene, benzocyclobutene (BCB), or others, and examples of the inorganic material may include Al_2O_3 , SiO_2 , SiN_x , or others. The organic material layer may be bonded under high vacuum, and the inorganic material layer may be bonded under high vacuum after flattening the surface of the first bonding layer by, for example, chemical mechanical polishing, followed by adjusting surface energy

through plasma treatment. The first bonding layer **3530** may be formed of spin-on-glass or may be a metal bonding layer formed of AuSn or the like. For the metal bonding layer, an insulation layer may be disposed on the first LED stack **3230** to secure electrical insulation between the first LED stack **3230** and the metal bonding layer. Furthermore, a reflective layer may be further disposed between the first bonding layer **3530** and the first LED stack **3230** to prevent light generated from the first LED stack **3230** from entering the second LED stack **3330**.

[0507] The second bonding layer **3550** couples the second LED stack **3330** to the third LED stack **3430**. The second bonding layer **3550** may be interposed between the second LED stack **3330** and the third-2 ohmic electrode **3450** to bond the second LED stack **3330** to the third-2 ohmic electrode **3450**. The second bonding layer **3550** may be formed of substantially the same bonding material as the first bonding layer **3530**. Furthermore, an insulation layer and/or a reflective layer may be further disposed between the second LED stack **3330** and the second bonding layer **3550**.

[0508] When the first bonding layer **3530** and the second bonding layer **3550** are formed of a light transmissive material, and the second-2 ohmic electrode **3350** and the third-2 ohmic electrode **3450** are formed of a transparent oxide material, some fractions of light generated from the first LED stack **3230** may be emitted through the second LED stack **3330** after passing through the first bonding layer **3530** and the second-2 ohmic electrode **3350**, and may also be emitted through the third LED stack **3430** after passing through the second bonding layer **3550** and the third-2 ohmic electrode **3450**. In addition, some fractions of light generated from the second LED stack **3330** may be emitted through the third LED stack **3430** after passing through the second bonding layer **3550** and the third-2 ohmic electrode **3450**.

[0509] In this case, light generated from the first LED stack **3230** should be prevented from being absorbed by the second LED stack **3330** while passing through the second LED stack **3330**. As such, light generated from the first LED stack **3230** may have a smaller bandgap than the second LED stack **3330**, and thus, may have a longer wavelength than light generated from the second LED stack **3330**.

[0510] In addition, in order to prevent light generated from the second LED stack **3330** from being absorbed by the third LED stack **3430** while passing through the third LED stack **3430**, light generated from the second LED stack **3330** may have a longer wavelength than light generated from the third LED stack **3430**.

[0511] When the first bonding layer **3530** and the second bonding layer **3550** are formed of opaque materials, the reflective layers are interposed between the first LED stack **3230** and the first bonding layer **3530**, and between the second LED stack **3330** and the second bonding layer **3550**, respectively, to reflect light having been generated from the first LED stack **3230** and entering the first bonding layer **3530**, and light having been generated from the second LED stack **3330** and entering the second bonding layer **3550**. The reflected light may be emitted through the first LED stack **3230** and the second LED stack **3330**.

[0512] The upper insulation layer **3610** may cover the first to third LED stacks **3230**, **3330**, and **3430**. In particular, the upper insulation layer **3610** may cover side surfaces of the second LED stack **3330** and the third LED stack **3430**, and may also cover the side surface of the first LED stack **3230**.

[0513] The upper insulation layer 3610 has openings that expose the first to third the through-hole vias 3270a, 3270b, 3270c, and openings that expose the first conductivity type semiconductor layer 3330a of the second LED stack 3330, the first conductivity type semiconductor layer 3430a of the third LED stack 3430, the second-2 ohmic electrode 3350, and the third-2 ohmic electrode 3450.

[0514] The upper insulation layer 3610 may be formed of any insulation material, for example, silicon oxide or silicon nitride, without being limited thereto.

[0515] The connector 3710 electrically connects the first-1 ohmic electrode 3290a, the second-1 ohmic electrode 3390, and the third-1 ohmic electrode 3490 to one another. The connector 3710 is formed on the upper insulation layer 3610, and is insulated from the second conductivity type semiconductor layer 3430b of the third LED stack 3430, the second conductivity type semiconductor layer 3330b of the second LED stack 3330, and the second conductivity type semiconductor layer 3230b of the first LED stack 3230.

[0516] The connector 3710 may be formed of substantially the same material as the second-1 ohmic electrode 3390 and the third-1 ohmic electrode 3490, and thus, may be formed together with the second-1 ohmic electrode 3390 and the third-1 ohmic electrode 3490. Alternatively, the connector 3710 may be formed of a different conductive material from the second-1 ohmic electrode 3390 or the third-1 ohmic electrode 3490, and thus, may be separately formed in a different process from the second-1 ohmic electrode 3390 and/or the third-1 ohmic electrode 3490.

[0517] The connector 3720 may electrically connect the second-1 ohmic electrode 3350, for example, the barrier layer 3350b, to the second through-hole via 3270b. The connector 3730 electrically connects the third-1 ohmic electrode, for example, the barrier layer 3450b, to the third through-hole via 3270c. The connector 3720 may be electrically insulated from the first LED stack 3230 by the upper insulation layer 3610. The connector 3730 may also be electrically insulated from the second LED stack 3330 and the first LED stack 3230 by the upper insulation layer 3610.

[0518] The connectors 3720, 3730 may be formed together by the same process. The connector 3720, 3730 may also be formed together with the connector 3710. Furthermore, the connectors 3720, 3730 may be formed of substantially the same material as the second-1 ohmic electrode 3390 and the third-1 ohmic electrode 3490, and may be formed together therewith. Alternatively, the connectors 3720, 3730 may be formed of a different conductive material from the second-1 ohmic electrode 3390 or the third-1 ohmic electrode 3490, and thus may be separately formed by a different process from the second-1 ohmic electrode 3390 and/or the third-1 ohmic electrode 3490.

[0519] The lower insulation layer 3750 covers a lower surface of the substrate 3210. The lower insulation layer 3750 may include openings which expose the first to third through-hole vias 3270a, 3270b, 3270c at a lower side of the substrate 3210, and may also include openings which expose the lower surface of the substrate 3210.

[0520] The electrode pads 3770a, 3770b, 3770c, and 3770d are disposed on the lower surface of the substrate 3210. The electrode pads 3770a, 3770b, and 3770c are connected to the through-hole vias 3270a, 3270b, and 3270c through the openings of the insulation layer 3750, and the electrode pad 3770d is connected to the substrate 3210.

[0521] The electrode pads 3770a, 3770b, and 3770c are provided to each pixel to be electrically connected to the first to third LED stacks 3230, 3330, and 3430 of each pixel, respectively. Although the electrode pad 3770d may also be provided to each pixel, the substrate 3210 is continuously disposed over a plurality of pixels, which may obviate the need for providing the electrode pad 3770d to each pixel.

[0522] The electrode pads 3770a, 3770b, 3770c, 3770d are bonded to the circuit board 3510, thereby providing a display apparatus.

[0523] Next, a method of manufacturing the display apparatus according to an exemplary embodiment will be described.

[0524] FIG. 61A to FIG. 61B are schematic plan views and cross-sectional views illustrating a method of manufacturing the display apparatus according to an exemplary embodiment. Each of the cross-sectional views is taken along a line shown in each corresponding plan view.

[0525] Referring to FIGS. 61A and 61B, a first LED stack 3230 is grown on a substrate 3210. The substrate 3210 may be, for example, a GaAs substrate. The first LED stack 3230 is formed of AlGaInP-based semiconductor layers, and includes a first conductivity type semiconductor layer 3230a, an active layer, and a second conductivity type semiconductor layer 3230b. A distributed Bragg reflector 3220 may be formed prior to growth of the first LED stack 3230. The distributed Bragg reflector 3220 may have a stack structure formed by repeatedly stacking, for example, AlAs/AlGaAs layers.

[0526] Then, grooves are formed on the first LED stack 3230 and the substrate 3210 through photolithography and etching. The grooves may be formed to pass through the substrate 3210 or may be formed to a predetermined depth in the substrate 3210, as shown in FIG. 61B.

[0527] Then, an insulation layer 3250 is formed to cover sidewalls of the grooves and through-hole vias 3270a, 3270b, 3270c are formed to fill the grooves. The through-hole vias 3270a, 3270b, and 3270c may be formed by, for example, forming an insulation layer to cover the sidewalls of the grooves, filling the groove with a conductive material layer or conductive pastes through plating, and removing the insulation and the conductive material layer from an upper surface of the first LED stack 3230 through chemical mechanical polishing.

[0528] Referring to FIG. 62A and FIG. 62B, a second LED stack 3330 and a second-2 ohmic electrode 3350 may be coupled to the first LED stack 3230 via the first bonding layer 3530.

[0529] The second LED stack 3330 is grown on a second substrate, and the second-2 ohmic electrode 3350 is formed on the second LED stack 3330. The second LED stack 3330 is formed of AlGaInP-based or AlGaInN-based semiconductor layers, and may include a first conductivity type semiconductor layer 3330a, an active layer, and a second conductivity type semiconductor layer 3330b. The second substrate may be a substrate on which AlGaInP-based semiconductor layers may be grown thereon, for example, a GaAs substrate, or a substrate on which AlGaInN-based semiconductor layers may be grown thereon, for example, a sapphire substrate. The composition ratio of Al, Ga, and In for the second LED stack 3330 may be determined such that the second LED stack 3330 can emit green light. The second-2 ohmic electrode 3350 forms ohmic contact with the second conductivity type semiconductor layer 3330b, for

example, a p-type semiconductor layer. The second-2 ohmic electrode **3350** may include a reflective layer **3350a**, which reflects light generated from the second LED stack **3330**, and a barrier layer **3350b**.

[0530] The second-2 ohmic electrode **3350** is disposed to face the first LED stack **3230** and is coupled to the first LED stack **3230** by the first bonding layer **3530**. Thereafter, the second substrate is removed from the second LED stack **3330** to expose the first conductivity type semiconductor layer **3330a** by chemical etching or laser lift-off. A roughened surface may be formed on the exposed first conductivity type semiconductor layer **3330a** by surface texturing.

[0531] According to an exemplary embodiment, an insulation layer and a reflective layer may be further formed on the first LED stack **3230** before formation of the first bonding layer **3530**.

[0532] Referring to FIG. 63A and FIG. 63B, a third LED stack **3430** and a third-2 ohmic electrode **3450** may be coupled to the second LED stack **3330** via the second bonding layer **3550**.

[0533] The third LED stack **3430** is grown on a third substrate, and the third-2 ohmic electrode **3450** is formed on the third LED stack **3430**. The third LED stack **3430** is formed of AlGaInN-based semiconductor layers, and may include a first conductivity type semiconductor layer **3430a**, an active layer, and a second conductivity type semiconductor layer **3430b**. The third substrate is a substrate on which GaN-based semiconductor layers may be grown thereon, and is different from the first substrate **3210**. The composition ratio of AlGaInN for the third LED stack **3430** may be determined such that the third LED stack **3430** can emit blue light. The third-2 ohmic electrode **3450** forms ohmic contact with the second conductivity type semiconductor layer **3430b**, for example, a p-type semiconductor layer. The third-2 ohmic electrode **3450** may include a reflective layer **3450a**, which reflects light generated from the third LED stack **3430**, and a barrier layer **3450b**.

[0534] The third-2 ohmic electrode **3450** is disposed to face the second LED stack **3330** and is coupled to the second LED stack **3330** by the second bonding layer **3550**. Thereafter, the third substrate is removed from the third LED stack **3430** to expose the first conductivity type semiconductor layer **3430a** by chemical etching or laser lift-off. A roughened surface may be formed on the exposed first conductivity type semiconductor layer **3430a** by surface texturing.

[0535] According to an exemplary embodiment, an insulation layer and a reflective layer may be further formed on the second LED stack **3330** before formation of the second bonding layer **3550**.

[0536] Referring to FIG. 64A and FIG. 64B, in each of pixel regions, the third LED stack **3430** is patterned to remove the third LED stack **3430** other than in the third subpixel B. In a region of the third subpixel B, an indentation is formed on the third LED stack **3430** to expose the barrier layer **3450b** through the indentation.

[0537] Then, in regions other than the third subpixel B, the third-2 ohmic electrode **3450** and the second bonding layer **3550** are removed to expose the second LED stack **3330**. As such, the third-2 ohmic electrode **3450** is restrictively placed near the region of the third subpixel B.

[0538] In each pixel region, the second LED stack **3330** is patterned to remove the second LED stack **3330** in regions

other than the second subpixel G. In the region of the second subpixel G, the second LED stack **3330** partially overlaps the third LED stack **3430**.

[0539] By patterning the second LED stack **3330**, the second-2 ohmic electrode **3350** is exposed. The second LED stack **3330** may include an indentation, and the second-2 ohmic electrode **3350**, for example, the barrier layer **3350b**, may be exposed through the indentation.

[0540] Thereafter, the second-2 ohmic electrode **3350** and the first bonding layer **3530** are removed to expose the first LED stack **3230**. As such, the second-2 ohmic electrode **3350** is disposed near the region of the second subpixel G. On the other hand, the first to third through-hole vias **3270a**, **3270b**, and **3270c** are also exposed together with the first LED stack **3230**.

[0541] In each pixel region, the first conductivity type semiconductor layer **3230a** is exposed by patterning the second conductivity type semiconductor layer **3230b** of the first LED stack **3230**. As shown in FIG. 64A, the first conductivity type semiconductor layer **3230a** may be exposed in an elongated shape, without being limited thereto.

[0542] Furthermore, the pixel regions are divided from one another by patterning the first LED stack **3230**. As such, a region of the first subpixel R is defined. Here, the distributed Bragg reflector **3220** may also be divided. Alternatively, the distributed Bragg reflector **3220** may be continuously disposed over the plurality of pixels, rather than being divided. Further, the first conductivity type semiconductor layer **3230a** may also be continuously disposed over the plurality of pixels.

[0543] Referring to FIG. 65A and FIG. 65B, a first-1 ohmic electrode **3290a** and a first-2 ohmic electrode **3290b** are formed on the first LED stack **3230**. The first-1 ohmic electrode **3290a** may be formed of, for example, Au—Te or Au—Ge alloys on the exposed first conductivity type semiconductor layer **3230a**. The first-2 ohmic electrode **3290b** may be formed of, for example, Au—Be or Au—Zn alloys on the second conductivity type semiconductor layer **3230b**. The first-2 ohmic electrode **3290b** may be formed prior to the first-1 ohmic electrode **3290a**, or vice versa. The first-2 ohmic electrode **3290b** may be connected to the first through-hole via **3270a**. On the other hand, the first-1 ohmic electrode **3290a** may include a pad region and an extension, which may extend from the pad region towards the first through-hole via **3270a**.

[0544] For current spreading, the first-2 ohmic electrode **3290b** may be disposed to at least partially surround the first-1 ohmic electrode **3290a**. Although each of the first-1 ohmic electrode **3290a** and the first-2 ohmic electrode **3290b** is being illustrated as having an elongated shape in FIG. 65A, the inventive concepts are not limited thereto. Alternatively, each of the first-1 ohmic electrode **3290a** and the first-2 ohmic electrode **3290b** may have a circular shape, for example.

[0545] Referring to FIG. 66A and FIG. 66B, an upper insulation layer **3610** is formed to cover the first to third LED stacks **3230**, **3330**, **3430**. The upper insulation layer **3610** may cover the first-1 ohmic electrode **3290a** and the first-2 ohmic electrode **3290b**. The upper insulation layer **3610** may also cover side surfaces of the first to third LED stacks **3230**, **3330**, and **3430**, and a side surface of the distributed Bragg reflector **3220**.

[0546] The upper insulation layer 3610 may have an opening 3610a which exposes the first-1 ohmic electrode 3290a, openings 3610b, 3610c which expose the barrier layers 3350b, 3450b, openings 3610d, 3610e which expose the second and third through-hole vias 3270b, 3270c, and openings 3610f, 3610g which expose the first conductivity type semiconductor layers 3330a, 3430a of the second LED stack 3330 and the third LED stack 3430.

[0547] Referring to FIG. 67A and FIG. 67B, a second-1 ohmic electrode 3390, a third-1 ohmic electrode 3490 and connectors 3710, 3720, 3730 are formed. The second-1 ohmic electrode 3390 is formed in the opening 3610f to form ohmic contact with the first conductivity type semiconductor layer 3330a, and the third-1 ohmic electrode 3490 is formed in the opening 3610g to form ohmic contact with the first conductivity type semiconductor layer 3430a.

[0548] The connector 3710 electrically connects the second-1 ohmic electrode 3390 and the third-1 ohmic electrode 3490 to the first-1 ohmic electrode 3290a. The connector 3710 may be connected to, for example, the first-1 ohmic electrode 3290a exposed in the opening 3610a. The connector 3710 is formed on the upper insulation layer 3610 to be insulated from the second conductivity type semiconductor layers 3230b, 3330b, and 3430b.

[0549] The connector 3720 electrically connects the second-2 ohmic electrode 3350 to the second through-hole via 3270b, and the connector 3730 electrically connects the third-2 ohmic electrode 3450 to the third through-hole via 3270c. The connectors 3720, 3730 are disposed on the upper insulation layer 3610 to prevent short circuit to the first to third LED stacks 3230, 3330, and 3430.

[0550] The second-1 ohmic electrode 3390, the third-1 ohmic electrode 3490, and the connectors 3710, 3720, 3730 may be formed of substantially the same material by the same process. However, the inventive concepts are not limited thereto. Alternatively, the second-1 ohmic electrode 3390, the third-1 ohmic electrode 3490, and the connectors 3710, 3720, 3730 may be formed of different materials by different processes.

[0551] Thereafter, referring to FIG. 68A and FIG. 68B, a lower insulation layer 3750 is formed on a lower surface of the substrate 3210. The lower insulation layer 3750 has openings which expose the first to third the through-hole vias 3270a, 3270b, 3270c, and may also have opening(s) which expose the lower surface of the substrate 3210.

[0552] Electrode pads 3770a, 3770b, 3770c, 3770d are formed on the lower insulation layer 3750. The electrode pads 3770a, 3770b, 3770c are connected to the first to third the through-hole vias 3270a, 3270b, 3270c, respectively, and the electrode pad 3770d is connected to the substrate 3210.

[0553] Accordingly, the electrode pad 3770a is electrically connected to the second conductivity type semiconductor layer 3230b of the first LED stack 3230 through the first through-hole via 3270a, the electrode pad 3770b is electrically connected to the second conductivity type semiconductor layer 3330b of the second LED stack 3330 through the second through-hole via 3270b, and the electrode pad 3770c is electrically connected to the second conductivity type semiconductor layer 3430b of the third LED stack 3430 through the third through-hole via 3270c. The first conductivity type semiconductor layers 3230a, 3330a, 3430a of the first to third LED stacks 3230, 3330, 3430 are commonly electrically connected to the electrode pad 3770d.

[0554] In this manner, a display apparatus according to an exemplary embodiment may be formed by bonding the electrode pads 3770a, 3770b, 3770c, 3770d of the substrate 3210 to the circuit board 3510 shown in FIG. 56. As described above, the circuit board 3510 may include an active circuit or a passive circuit, whereby the display apparatus can be driven in an active matrix manner or in a passive matrix manner.

[0555] FIG. 69 is a cross-sectional view of a light emitting diode pixel for a display according to another exemplary embodiment.

[0556] Referring to FIG. 69, the light emitting diode pixel 3001 of the display apparatus according to an exemplary embodiment is generally similar to the light emitting diode pixel 3000 of the display apparatus of FIG. 57, except that the second LED stack 3330 covers most of the first LED stack 3230 and the third LED stack 3430 covers most of the second LED stack 3330. In this manner, light generated from the first subpixel R is emitted to the outside after substantially passing through the second LED stack 3330 and the third LED stack 3430, and light generated from the second LED stack 3330 is emitted to the outside after substantially passing through the third LED stack 3430.

[0557] The first LED stack 3230 may include an active layer having a narrower bandgap than the second LED stack 3330 and the third LED stack 3430 to emit light having a longer wavelength than the second LED stack 3330 and the third LED stack 3430, and the second LED stack 3330 may include an active layer having a narrower bandgap than the third LED stack 3430 to emit light having a longer wavelength than the third LED stack 3430.

[0558] FIG. 70 is an enlarged top view of one pixel of a display apparatus according to an exemplary embodiment, and FIG. 71A and FIG. 71B are cross-sectional views taken along lines G-G and H-H of FIG. 70, respectively.

[0559] Referring to FIG. 70, FIG. 71A, and FIG. 71B, the pixel according to an exemplary embodiment is generally similar to the pixel of FIG. 59, FIG. 60A, FIG. 60B, and FIG. 60C, except that the second LED stack 3330 covers most of the first LED stack 3230 and the third LED stack 3430 covers most of the second LED stack 3330. The first to third through-hole vias 3270a, 3270b, 3270c may be disposed outside the second LED stack 3330 and the third LED stack 3430.

[0560] In addition, a portion of the first-1 ohmic electrode 3290a and a portion of the second-1 ohmic electrode 3390 may be disposed under the third LED stack 3430. As such, the first-1 ohmic electrode 3290a may be formed before the second LED stack 3330 is coupled to the first LED stack 3230, and the second-1 ohmic electrode 3390 may also be formed before the third LED stack 3430 is coupled to the second LED stack 3330.

[0561] Furthermore, light generated from the first LED stack 3230 is emitted to the outside after substantially passing through the second LED stack 3330 and the third LED stack 3430, and light generated from the second LED stack 3330 is emitted to the outside after substantially passing through the third LED stack 3430. Accordingly, the first bonding layer 3530 and the second bonding layer 3550 are formed of light transmissive materials, and the second-2 ohmic electrode 3350 and the third-2 ohmic electrode 3450 are composed of transparent conductive layers.

[0562] On the other hand, as shown in FIGS. 71A and 71B, an indentation may be formed on the third LED stack

3430 to expose the third-2 ohmic electrode **3450**, and an indentation is continuously formed on the third LED stack **3430** and the second LED stack **3330** to expose the second-2 ohmic electrode **3350**. The second-2 ohmic electrode **3350** and the third-2 ohmic electrode **3450** are electrically connected to the second through-hole via **3270b**, and the third through-hole via **3270c** through the connectors **3720**, **3730**, respectively.

[0563] Furthermore, the indentation may be formed on the third LED stack **3430** to expose the second-1 ohmic electrode **3390** formed on the first conductivity type semiconductor layer **3330a** of the second LED stack **3330**, and the indentation may be continuously formed on the third LED stack **3430** and the second LED stack **3330** to expose the first-1 ohmic electrode **3290a** formed on the first conductivity type semiconductor layer **3230a** of the first LED stack **3230**. The connector **3710** may connect the first-1 ohmic electrode **3290a** and the second-1 ohmic electrode **3390** to the third-1 ohmic electrode **3490**. The third-1 ohmic electrode **3490** may be formed together with the connector **3710** and may be connected to the pad regions of the first-1 ohmic electrode **3290a** and the second-1 ohmic electrode **3390**.

[0564] The first-1 ohmic electrode **3290a** and the second-1 ohmic electrode **3390** are partially disposed under the third LED stack **3430**, but the inventive concepts are not limited thereto. For example, the portions of the first-1 ohmic electrode **3290a** and the second-1 ohmic electrode **3390** disposed under the third LED stack **3430** may be omitted. Furthermore, the second-1 ohmic electrode **3390** may be omitted and the connector **3710** may form ohmic contact with the first conductivity type semiconductor layer **3330a**.

[0565] According to exemplary embodiments, a plurality of pixels may be formed at the wafer level through wafer bonding, and thus, the process of individually mounting light emitting diodes may be obviated or substantially reduced.

[0566] Furthermore, since the through-hole vias **3270a**, **3270b**, **3270c** are formed in the substrate **3210** and used as current paths, the substrate **3210** may not need to be removed. Accordingly, a growth substrate used for growth of the first LED stack **3230** can be used as the substrate **3210** without being removed from the first LED stack **3230**.

[0567] FIG. 72 is a schematic cross-sectional view of a light emitting diode (LED) stack for a display according to an exemplary embodiment.

[0568] Referring to FIG. 72, the light emitting diode stack **4000** for a display may include a support substrate **4051**, a first LED stack **4023**, a second LED stack **4033**, a third LED stack **4043**, a reflective electrode **4025**, an ohmic electrode **4026**, a first insulating layer **4027**, a second insulating layer **4028**, a interconnection line **4029**, a second-p transparent electrode **4035**, a third-p transparent electrode **4045**, a first color filter **4037**, a second color filter **4047**, hydrophilic material layers **4052**, **4054**, and **4056**, a first bonding layer **4053** (a lower bonding to layer), a second bonding layer **4055** (an intermediate bonding layer), and a third bonding layer **4057** (an upper bonding layer).

[0569] The support substrate **4051** supports semiconductor stacks **4023**, **4033**, and **4043**. The support substrate **4051** may have a circuit on a surface thereof or an inside thereof, but is not limited thereto. The support substrate **4051** may include, for example, a glass, a sapphire substrate, a Si substrate, or a Ge substrate.

[0570] The first LED stack **4023**, the second LED stack **4033**, and the third LED stack **4043** each include first conductivity type semiconductor layers **4023a**, **4033a**, and **4043a**, second conductivity type semiconductor layers **4023b**, **4033b**, and **4043b**, and active layers interposed between the first conductivity type semiconductor layers and the second conductivity type semiconductor layers. The active layer may have a multiple quantum well structure.

[0571] The first LED stack **4023** may be an inorganic LED that emits red light, the second LED stack **4033** may be an inorganic LED that emits green light, and the third LED stack **4043** may be an inorganic LED that emits blue light. The first LED stack **4023** may include a GaInP-based well layer, and the second LED stack **4033** and the third LED stack **4043** may include a GaInN-based well layer. However, the inventive concepts are limited thereto, and when the LED stacks include micro LEDs, the first LED stack **4023** may emit any one of red, green, and blue light, and the second and third LED stacks **4033** and **4043** may emit a different one of the red, green, and blue light without adversely affecting operation or requiring color filters due to its small form factor.

[0572] Opposite surfaces of each LED stack **4023**, **4033**, or **4043** are an n-type semiconductor layer and a p-type semiconductor layer, respectively. The illustrated exemplary embodiment describes a case in which the first conductivity type semiconductor layers **4023a**, **4033a**, and **4043a** of each of the first to third LED stacks **4023**, **4033**, and **4043** are n-type, and the second conductivity type semiconductor layers **4023b**, **4033b**, and **4043b** thereof are p-type. A roughened surface may be formed on upper surfaces of the first to third LED stacks **4023**, **4033**, and **4043**. However, the inventive concepts are not limited thereto, and the type of the semiconductor types of the upper surface and the lower surface of each of the LED stacks may be reversed.

[0573] The first LED stack **4023** is disposed to be adjacent to the support substrate **4051**, the second LED stack **4033** is disposed on the first LED stack **4023**, and the third LED stack **4043** is disposed on the second LED stack **4033**. Since the first LED stack **4023** emits light of the wavelength longer than the wavelengths of the second and third LED stacks **4033** and **4043**, light generated in the first LED stack **4023** may be transmitted through the second and third LED stacks **4033** and **4043** and may be emitted to the outside. In addition, since the second LED stack **4033** emits light of the wavelength longer than the wavelength of the third LED stack **4043**, light generated in the second LED stack **4033** may be transmitted through the third LED stack **4043** and may be emitted to the outside.

[0574] The reflective electrode **4025** is in ohmic contact with the second conductivity type semiconductor layer of the first LED stack **4023** and reflects light generated in the first LED stack **4023**. For example, the reflective electrode **4025** may include an ohmic contact layer **4025a** and a reflective layer **4025b**.

[0575] The ohmic contact layer **4025a** is partially in contact with the second conductivity type semiconductor layer, that is, a p-type semiconductor layer. In order to prevent light absorption by the ohmic contact layer **4025a**, an area in which the ohmic contact layer **4025a** is in contact with the p-type semiconductor layer may not exceed about 50% of a total area of the p-type semiconductor layer. The reflective layer **4025b** covers the ohmic contact layer **4025a** and also covers the first insulating layer **4027**. As illustrated,

the reflective layer **4025b** may substantially cover the entirety of the ohmic contact layer **4025a**, or a portion of the ohmic contact layer **4025a**.

[0576] The reflective layer **4025b** covers the first insulating layer **4027**, such that an omnidirectional reflector may be formed by a stack of the first LED stack **4023** having a relatively high refractive index and the first insulating layer **4027** and the reflective layer **4025b** having a relatively low refractive index. The reflective layer **4025b** covers about 50% or more of the area of the first LED stack **4023**, preferably, most of the region of the first LED stack **4023**, thereby improving light efficiency.

[0577] The ohmic contact layer **4025a** and the reflective layer **4025b** may be formed of a metal layer containing gold (Au). The ohmic contact layer **4025a** may be formed of, for example, an Au—Zn alloy or an Au—Be alloy. The reflective layer **4025b** may be formed of a metal layer having high reflectivity with respect to light generated in the first LED stack **4023**, for example, red light, such as aluminum (Al), silver (Ag), or gold (Au). In particular, Au may have relatively low reflectivity with respect to light generated in the second LED stack **4033** and the third LED stack **4043**, for example, green light or blue light, and thus, may reduce light interference by absorbing light generated in the second and third LED stacks **4033** and **4043** and traveling toward the support substrate **4051**.

[0578] The first insulating layer **4027** is disposed between the support substrate **4051** and the first LED stack **4023**, and has an opening exposing the first LED stack **4023**. The ohmic contact layer **4025a** is connected to the first LED stack **4023** within the opening of the first insulating layer **4027**.

[0579] The ohmic electrode **4026** is in ohmic contact with the first conductivity type semiconductor layer **4023a** of the first LED stack **4023**. The ohmic electrode **4026** may be disposed on the first conductivity type semiconductor layer **4023a** exposed by partially removing the second conductivity type semiconductor layer **4023b**. Although FIG. 72 illustrates one ohmic electrode **4026**, a plurality of ohmic electrodes **4026** are aligned on a plurality of regions on the support substrate **4051**. The ohmic electrode **4026** may be formed of, for example, an Au—Te alloy or an Au—Ge alloy.

[0580] The second insulating layer **4028** is disposed between the support substrate **4051** and the reflective electrode **4025** to cover the reflective electrode **4025**. The second insulating layer **4028** has an opening exposing the ohmic electrode **4026**. The second insulating layer **4028** may be formed of SiO₂ or SOG.

[0581] The interconnection line **4029** is disposed between the second insulating layer **4028** and the support substrate **4051**, and is connected to the ohmic electrode **4026** through the opening of the second insulating layer **4028**. The interconnection line **4029** may connect a plurality of ohmic electrodes **4026** to one another on the support substrate **4051**.

[0582] The second-p transparent electrode **4035** is in ohmic contact with the second conductivity type semiconductor layer **4033b** of the second LED stack **4033**, that is, the p-type semiconductor layer. The second-p transparent electrode **4035** may be formed of a metal layer or a conductive oxide layer which is transparent to red light and green light.

[0583] The third-p transparent electrode **4045** is in ohmic contact with the second conductivity type semiconductor

layer **4043b** of the third LED stack **4043**, that is, the p-type semiconductor layer. The third-p transparent electrode **4045** may be formed of a metal layer or a conductive oxide layer which is transparent to red light, green light, and blue light.

[0584] The reflective electrode **4025**, the second-p transparent electrode **4035**, and the third-p transparent electrode **4045** may be in ohmic contact with the p-type semiconductor layer of each LED stack to assist in current dispersion.

[0585] The first color filter **4037** may be disposed between the first LED stack **4023** and the second LED stack **4033**. In addition, the second color filter **4047** may be disposed between the second LED stack **4033** and the third LED stack **4043**. The first color filter **4037** transmits light generated in the first LED stack **4023** and reflects light generated in the second LED stack **4033**. The second color filter **4047** transmits light generated in the first and second LED stacks **4023** and **4033** and reflects light generated in the third LED stack **4043**. Accordingly, light generated in the first LED stack **4023** may be emitted to the outside through the second LED stack **4033** and the third LED stack **4043**, and light generated in the second LED stack **4033** may be emitted to the outside through the third LED stack **4043**. Further, it is possible to prevent light generated in the second LED stack **4033** from being incident on the first LED stack **4023** and lost, or light generated in the third LED stack **4043** from being incident on the second LED stack **4033** and lost.

[0586] According to some exemplary embodiments, the first color filter **4037** may also reflect light generated in the third LED stack **4043**. According to some exemplary embodiments, when the LED stacks include micro LEDs, the color filters may be omitted due to the small form factor of the micro LEDs.

[0587] The first and second color filters **4037** and **4047** may be, for example, a low pass filter that passes only a low frequency region, that is, a long wavelength region, a band pass filter that passes only a predetermined wavelength band, or a band stop filter that blocks only the predetermined wavelength band. In particular, the first and second color filters **4037** and **4047** may be formed by alternately stacking insulating layers having different refractive indices, and may be formed by alternately stacking, for example, TiO₂ and SiO₂, Ta₂O₅ and SiO₂, Nb₂O₅ and SiO₂, HfO₂ and SiO₂, or ZrO₂ and SiO₂. Further, the first and/or second color filter **4037** and/or **4047** may include a distributed Bragg reflector (DBR). The distributed Bragg reflector may be formed by alternately stacking insulating layers having different refractive indices. Further, a stop band of the distributed Bragg reflector may be controlled by adjusting a thickness of TiO₂ and SiO₂.

[0588] The first bonding layer **4053** couples the first LED stack **4023** to the support substrate **4051**. As illustrated, the interconnection line **4029** may be in contact with the first bonding layer **4053**. In addition, the interconnection line **4029** is disposed below some regions of the second insulating layer **4028**, and a region of the second insulating layer **4028** that does not have the interconnection line **4029** may be in contact with the first bonding layer **4053**. The first bonding layer **4053** may be light transmissive or light non-transmissive. In particular, a contrast of the display apparatus may be improved by using an adhesive layer that absorbs light, such as black epoxy, as the first bonding layer **4053**.

[0589] The first bonding layer **4053** may be in direct contact with the support substrate **4051**, but as illustrated,

the hydrophilic material layer **4052** may be disposed on an interface between the support substrate **4051** and the first bonding layer **4053**. The hydrophilic material layer **4052** may change a surface of the support substrate **4051** to be hydrophilic to improve adhesion of the first bonding layer **4053**. As used herein, the bonding layer and the hydrophilic material layer may collectively be referred to as a buffer layer.

[0590] The first bonding layer **4053** has a strong adhesion to the hydrophilic material layer, while it has a weak adhesion to a hydrophobic material layer. Therefore, peeling may occur at a portion in which the adhesion is weak. The hydrophilic material layer **4052** according to an exemplary embodiment may change a hydrophobic surface to be hydrophilic to enhance the adhesion of the first bonding layer **4053**, thereby preventing the occurrence of the peeling.

[0591] The hydrophilic material layer **4052** may also be formed by depositing, for example, SiO_2 , or others on the surface of the support substrate **4051**, and may also be formed by treating the surface of the support substrate **4051** with plasma to modify the surface. The surface modified layer increases surface energy to change hydrophobic property into hydrophilic property. In a case in which the second insulating layer **4028** has hydrophobic property, the hydrophilic material layer may also be disposed on the second insulating layer **4028**, and the first bonding layer **4052** may be in contact with the hydrophilic material layer on the second insulating layer **4028**.

[0592] The second bonding layer **4055** couples the second LED stack **4033** to the first LED stack **4023**. The second bonding layer **4055** may be disposed between the first LED stack **4023** and the first color filter **4037** and may be in contact with the first color filter **4037**. The second bonding layer **4055** may transmit light generated in the first LED stack **4023**. A hydrophilic material layer **4054** may be disposed in an interface between the first LED stack **4023** and the second bonding layer **4055**. The first conductivity type semiconductor layer **4023a** of the first LED stack **4023** generally exhibits hydrophobic property. Therefore, in a case in which the second bonding layer **4055** is in direct contact with the first conductivity type semiconductor layer **4023a**, the peeling is likely to occur at an interface between the second bonding layer **4055** and the first conductivity type semiconductor layer **4023a**.

[0593] The hydrophilic material layer **4054** according to an exemplary embodiment changes the surface of the first LED stack **4023** from having hydrophobic properties to having hydrophilic properties, and thus, improves the adhesion of the second bonding layer **4055**, thereby reducing or preventing the occurrence of the peeling. The hydrophilic material layer **4054** may be formed by depositing SiO_2 or modifying the surface of the first LED stack **4023** with plasma as described above.

[0594] A surface layer of the first color filter **4037** which is in contact with the second bonding layer **4055** may be a hydrophilic material layer, for example, SiO_2 . In a case in which the surface layer of the first color filter **4037** is not hydrophilic, the hydrophilic material layer may be formed on the first color filter **4037**, and the second bonding layer **4055** may be in contact with the hydrophilic material layer.

[0595] The third bonding layer **4057** couples the third LED stack **4043** to the second LED stack **4033**. The third bonding layer **4057** may be disposed between the second LED stack **4033** and the second color filter **4047** and may be

in contact with the second color filter **4047**. The third bonding layer **4057** transmits light generated in the first LED stack **4023** and the second LED stack **4033**. A hydrophilic material layer **4056** may be disposed in an interface between the second LED stack **4033** and the third bonding layer **4057**. The second LED stack **4033** may exhibit hydrophobic property, and as a result, in a case in which the third bonding layer **4057** is in direct contact with the second LED stack **4033**, the peeling is likely to occur at an interface between the third bonding layer **4057** and the second LED stack **4033**.

[0596] The hydrophilic material layer **4056** according to an exemplary embodiment changes the surface of the second LED stack **4033** from hydrophobic property into hydrophilic property, and thus, improves the adhesion of the third bonding layer **4057**, thereby preventing the occurrence of the peeling. The hydrophilic material layer **4056** may be formed by depositing SiO_2 or modifying the surface of the second LED stack **4033** with plasma as described above.

[0597] A surface layer of the second color filter **4047** which is in contact with the third bonding layer **4057** may be a hydrophilic material layer, for example, SiO_2 . In a case in which the surface layer of the second color filter **4047** is not hydrophilic, the hydrophilic material layer may be formed on the second color filter **4047** and the third bonding layer **4057** may be in contact with the hydrophilic material layer.

[0598] The first to third bonding layers **4053**, **4055**, and **4057** may be formed of light transmissive SOC, but is not limited thereto, and other transparent organic material layers or transparent inorganic material layers may be used. Examples of the organic material layer may include SU8, poly(methylmethacrylate) (PMMA), polyimide, parylene, benzocyclobutene (BCB), or others, and examples of the inorganic material layer may include Al_2O_3 , SiO_2 , SiN_x , or others. The organic material layers may be bonded at high vacuum and high pressure, and the inorganic material layers may be bonded by planarizing a surface with, for example, a chemical mechanical polishing process, changing surface energy using plasma or others, and then using the changed surface energy.

[0599] FIGS. 73A to 73F are schematic cross-sectional views illustrating a method of manufacturing the light emitting diode stack **4000** for a display according to the exemplary embodiment.

[0600] Referring to FIG. 73A, a first LED stack **4023** is first grown on a first substrate **4021**. The first substrate **4021** may be, for example, a GaAs substrate. The first LED stack **4023** is formed of an AlGaInP based semiconductor layers, and includes a first conductivity type semiconductor layer **4023a**, an active layer, and a second conductivity type semiconductor layer **4023b**.

[0601] Next, the second conductivity type semiconductor layer **4023b** is partially removed to expose the first conductivity type semiconductor layer **4023a**. Although FIG. 73A shows only one pixel region, the first conductivity type semiconductor layer **4023a** is partially exposed for each of the pixel regions.

[0602] A first insulating layer **4027** is formed on the first LED stack **4023** and is patterned to form openings. For example, SiO_2 is formed on the first LED stack **4023**, a photoresist is applied thereto, and a photoresist pattern is formed through photolithograph and development. Next, the first insulating layer **4027** in which the openings are formed may be formed by patterning SiO_2 using the photoresist

pattern as an etching mask. One of the openings of the first insulating layer 4027 may be disposed on the first conductivity type semiconductor layer 4023a, and other openings may be disposed on the second conductivity type semiconductor layer 4023b.

[0603] Thereafter, an ohmic contact layer 4025a and an ohmic electrode 4026 are formed in the openings of the first insulating layer 4027. The ohmic contact layer 4025a and the ohmic electrode 4026 may be formed using a lift-off technique. The ohmic contact layer 4025a may be first formed and the ohmic electrode 4026 may be then formed, or vice versa. In addition, according to an exemplary embodiment, the ohmic electrode 4026 and the ohmic contact layer 4025a may be simultaneously formed of the same material layer.

[0604] After the ohmic contact layer 4025a is formed, a reflective layer 4025b covering the ohmic contact layer 4025a and the first insulating layer 4027 is formed. The reflective layer 4025b may be formed using a lift-off technique. The reflective layer 4025b may also cover a portion of the ohmic contact layer 4025a, and may also cover substantially the entirety of the ohmic contact layer 4025a as illustrated. A reflective electrode 4025 is formed by the ohmic contact layer 4025a and the reflective layer 4025b.

[0605] The reflective electrode 4025 may be in ohmic contact with a p-type semiconductor layer of the first LED stack 4023, and may be thus referred to as a first p-type reflective electrode 4025. The reflective electrode 4025 is spaced apart from the ohmic electrode 4026, and is thus electrically insulated from the first conductivity type semiconductor layer 4023a.

[0606] A second insulating layer 4028 covering the reflective electrode 4025 and having an opening exposing the ohmic electrode 4026 is formed. The second insulating layer 4028 may be formed of, for example, SiO₂ or SOG.

[0607] Then, an interconnection line 4029 is formed on the second insulating layer 4028. The interconnection line 4029 is connected to the ohmic electrode 4026 through the opening of the second insulating layer 4028, and is thus electrically connected to the first conductivity type semiconductor layer 4023a.

[0608] Although the interconnection line 4029 is illustrated in FIG. 73A as covering the entire surface of the second insulating layer 4028, the interconnection line 4029 may be partially disposed on the second insulating layer 4028, and an upper surface of the second insulating layer 4028 may be exposed around the interconnection line 4029.

[0609] Although the illustrated exemplary embodiment shows one pixel region, the first LED stack 4023 disposed on the substrate 4021 may cover a plurality of pixel regions, and the interconnection line 4029 may be commonly connected to the ohmic electrodes 4026 formed on a plurality of regions. In addition, a plurality of interconnection lines 4029 may be formed on the substrate 4021.

[0610] Referring to FIG. 73B, a second LED stack 4033 is grown on a second substrate 4031 and a second-p transparent electrode 4035 and a first color filter 4037 are formed on the second LED stack 4033. The second LED stack 4033 may include a gallium nitride-based first conductivity type semiconductor layer 4033a, a second conductivity type semiconductor layer 4033b, and an active layer disposed therebetween, and the active layer may include a GaInN well layer. The second substrate 4031 is a substrate on which a gallium nitride-based semiconductor layer may be grown,

and is different from the first substrate 4021. A combination ratio of GaInN may be determined so that the second LED stack 4033 may emit green light. The second-p transparent electrode 4035 is in ohmic contact with the second conductivity type semiconductor layer 4033b.

[0611] The first color filter 4037 may be formed on the second-p transparent electrode 4035, and since details thereof are substantially the same as those described with reference to FIG. 72, detailed descriptions thereof will be omitted in order to avoid redundancy.

[0612] Referring to FIG. 73C, a third LED stack 4043 is grown on a third substrate 4041 and a third-p transparent electrode 4045 and a second color filter 4047 are formed on the third LED stack 4043. The third LED stack 4043 may include a gallium nitride-based first conductivity type semiconductor layer 4043a, a second conductivity type semiconductor layer 4043b, and an active layer disposed therebetween, and the active layer may include a GaInN well layer. The third substrate 4041 is a substrate on which a gallium nitride-based semiconductor layer may be grown, and is different from the first substrate 4021. A combination ratio of GaInN may be determined so that the third LED stack 4043 emits blue light. The third-p transparent electrode 4045 is in ohmic contact with the second conductivity type semiconductor layer 4043b.

[0613] Since the second color filter 4047 is substantially the same as that described with reference to FIG. 72, detailed descriptions thereof will be omitted in order to avoid redundancy.

[0614] Meanwhile, since the first LED stack 4023, the second LED stack 4033, and the third LED stack 4043 are grown on different substrates, the order of formation thereof is not particularly limited.

[0615] Referring to FIG. 73D, next, the first LED stack 4023 is coupled onto a support substrate 4051 through the first bonding layer 4053. Bonding material layers may be disposed on the support substrate 4051 and the second insulating layer 4028 and may be bonded to each other to form the first bonding layer 4053. The interconnection line 4029 is disposed to face the support substrate 4051.

[0616] Meanwhile, in a case in which a surface of the support substrate 4051 has hydrophobic property, a hydrophilic material layer 4052 may be first formed on the support substrate 4051. The hydrophilic material layer 4052 may also be formed by depositing a material layer such as SiO₂ on the surface of the support substrate 4051, or treating the surface of the support substrate 4051 with plasma or the like to increase surface energy. The surface of the support substrate 4051 is modified by the plasma treatment, and a surface modified layer having high surface energy may be formed on the surface of the support substrate 4051. The first bonding layer 4053 may be bonded to the hydrophilic material layer 4052, and adhesion of the first bonding layer 4053 is thus improved.

[0617] The first substrate 4021 is removed from the first LED stack 4023 using a chemical etching technique. Accordingly, the first conductivity type semiconductor layer of the first LED stack 4023 is exposed on the top surface. The exposed surface of the first conductivity type semiconductor layer 4023a may be textured to increase light extraction efficiency, and a light extraction structure, such as a roughened surface or others, may be thus formed on the surface of the first conductivity type semiconductor layer 4023a.

[0618] Referring to FIG. 73E, the second LED stack 4033 is coupled to the first LED stack 4023 through the second bonding layer 4055. The first color filter 4037 is disposed to face the first LED stack 4023 and is bonded to the second bonding layer 4055. The bonding material layers are disposed on the first LED stack 4023 and the first color filter 4037 and are bonded to each other to form the second bonding layer 4055.

[0619] Meanwhile, before the second bonding layer 4055 is formed, a hydrophilic material layer 4054 may be first formed on the first LED stack 4023. The hydrophilic material layer 4054 changes the surface of the first LED stack 4023 from having a hydrophobic property a hydrophilic property and thus improves the adhesion of the second bonding layer 4055. The hydrophilic material layer 4054 may also be formed by depositing a material layer such as SiO₂, or treating the surface of the first LED stack 4023 with plasma or others to increase surface energy. The surface of the first LED stack 4023 is modified by the plasma treatment, and a surface modified layer having high surface energy may be formed on the surface of the first LED stack 4023. The second bonding layer 4055 may be bonded to the hydrophilic material layer 4054, and adhesion of the second bonding layer 4055 is thus improved.

[0620] The second substrate 4031 may be separated from the second LED stack 4033 using a technique such as a laser lift-off or a chemical lift-off. In addition, in order to improve light extraction, a roughened surface may be formed on the exposed surface of the first conductivity type semiconductor layer 4033a using a surface texturing.

[0621] Referring to FIG. 73F, a hydrophilic material layer 4056 may be then formed on the second LED stack 4033. The hydrophilic material layer 4056 changes the surface of the second LED stack 4033 to a hydrophilic property and thus improves adhesion of the third bonding layer 4057. The hydrophilic material layer 4056 may also be formed by depositing a material layer such as SiO₂, or treating the surface of the second LED stack 4033 with plasma or the like to increase surface energy. However, in a case in which the surface of the second LED stack 4033 has a hydrophilic property, the hydrophilic material layer 4056 may be omitted.

[0622] Next, referring to FIGS. 72 and 73C, the third LED stack 4043 is coupled onto the second LED stack 4033 through the third bonding layer 4057. The second color filter 4047 is disposed to face the second LED stack 4033 and is bonded to the third bonding layer 4057. The bonding material layers are disposed on the second LED stack 4033 (or the hydrophilic material layer 4056) and the third color filter 4047, and are bonded to each other to form the third bonding layer 4057.

[0623] The third substrate 4041 may be separated from the third LED stack 4043 using a technique such as a laser lift-off or a chemical lift-off. Accordingly, as illustrated in FIG. 72, the LED stack for a display in which the first conductive layer 4043a of the third LED stack 4043 is exposed is provided. In addition, a roughened surface may be formed on the exposed surface of the first conductivity type semiconductor layer 4043a by a surface texturing.

[0624] A stack of the first to third LED stacks 4023, 4033, and 4043 disposed on the support substrate 4051 is patterned in a unit of pixel, and the patterned stacks are connected to each other using the interconnection lines, thereby making it

possible to provide a display apparatus. Hereinafter, a display apparatus according to exemplary embodiments will be described.

[0625] FIG. 74 is a schematic circuit diagram of a display apparatus according to an exemplary embodiment, and FIG. 75 is a schematic plan view of a display apparatus according to an exemplary embodiment.

[0626] Referring to FIGS. 74 and 75, the display apparatus according to an exemplary embodiment may be implemented to be driven in a passive matrix manner.

[0627] For example, since the LED stack for a display described with reference to FIG. 72 has a structure in which the first to third LED stacks 4023, 4033, and 4044 are stacked in a vertical direction, one pixel includes three light emitting diodes R, G, and B. Here, a first light emitting diode R may correspond to the first LED stack 4023, a second light emitting diode G may correspond to the second LED stack 4033, and a third light emitting diode B may correspond to the third LED stack 4043.

[0628] In FIGS. 74 and 75, one pixel includes the first to third light emitting diodes R, G, and B, and each light emitting diode corresponds to a sub-pixel. Anodes of the first to third light emitting diodes R, G, and B are connected to a common line, for example, a data line, and cathodes thereof are connected to different lines, for example, scan lines. For a first pixel, as an example, the anodes of the first to third light emitting diodes R, G, and B are commonly connected to a data line Vdata1, and cathodes thereof are connected to scan lines Vscan1-1, Vscan1-2, and Vscan1-3, respectively. Accordingly, the light emitting diodes R, G, and B in the same pixel may be separately driven.

[0629] In addition, each of the light emitting diodes R, G, and B may be driven by using pulse width modulation or change current intensity, thereby making it possible to adjust brightness of each sub-pixel.

[0630] Referring to again FIG. 75, a plurality of patterns are formed by patterning the stack described with reference to FIG. 72, and the respective pixels are connected to reflective electrodes 4025 and interconnection lines 4071, 4073, and 4075. As illustrated in FIG. 74, the reflective electrode 4025 may be used as a data line Vdata, and the interconnection lines 4071, 4073, and 4075 may be formed as the scan lines. Here, the interconnection line 4075 may be formed by the interconnection line 4029. The reflective electrode 4025 may electrically connect the first conductivity type semiconductor layers 4023a, 4033a, and 4043a of the first to third LED stacks 4023, 4033, and 4043 of the plurality of pixels to one another, and the interconnection line 4029 may be disposed to be substantially perpendicular to the reflective electrode 4025 to electrically connect the first conductivity type semiconductor layers 4023a of the plurality of pixels to each other.

[0631] The pixels may be arranged in a matrix form, and the anodes of the light emitting diodes R, G, and B of each pixel are commonly connected to the reflective electrode 4025 and the cathodes thereof are each connected to the interconnection lines 4071, 4073, and 4075 which are spaced apart from each other. Here, the interconnection lines 4071, 4073, and 4075 may be used as scan lines Vscan.

[0632] FIG. 76 is an enlarged plan view of one pixel of the display apparatus of FIG. 75, FIG. 77 is a schematic cross-sectional view taken along line A-A of FIG. 76, and FIG. 78 is a schematic cross-sectional view taken along line B-B of FIG. 76.

[0633] Referring back to FIGS. 75 to 78, in each pixel, a portion of the reflective electrode 4025, a portion of the second-p transparent electrode 4035, a portion of an upper surface of the second LED stack 4033, a portion of the third-p transparent electrode 4045, and an upper surface of the third LED stack 4043 are exposed to the outside.

[0634] The third LED stack 4043 may have a roughened surface 4043_r formed on the upper surface thereof. The roughened surface 4043_r may also be formed on the entirety of the upper surface of the third LED stack 4043, or on a portion of the upper surface of the third LED stack 4043.

[0635] A lower insulating layer 4061 may cover a side surface of each pixel. The lower insulating layer 4061 may be formed of a light transmissive material such as SiO₂, and in this case, the lower insulating layer 4061 may also cover substantially the entirety of the upper surface of the third LED stack 4043. Alternatively, the lower insulating layer 4061 according to an exemplary embodiment may include a light reflective layer or a light absorption layer to prevent light traveling from the first to third LED stacks 4023, 4033, and 4043 to the side surface, and in this case, the lower insulating layer 4061 at least partially exposes the upper surface of the third LED stack 4043. The lower insulating layer 4061 may include, for example, a distribution Bragg reflector or a metallic reflective layer, or an organic reflective layer on a transparent insulating layer, and may also include a light absorption layer such as black epoxy. The light absorption layer, such as black epoxy, may prevent light from being emitted to the outside of the pixels, thereby improving a contrast ratio between the pixels in the display apparatus.

[0636] The lower insulating layer 4061 may have an opening 4061_a exposing the upper surface of the third LED stack 4043, an opening 4061_b exposing the upper surface of the second LED stack 4033, an opening 4061_c exposing the third-p transparent electrode 4045, an opening 4061_d exposing the second-p transparent electrode 4035, and an opening 4061_e exposing the first p-type reflective electrode 4025. The upper surface of the first LED stack 4023 may not be exposed to the outside.

[0637] The interconnection line 4071 and the interconnection line 4073 may be formed on the support substrate 4051 in the vicinity of the first to third LED stacks 4023, 4033, and 4043, and may be disposed on the lower insulating layer 4061 to be insulated from the first p-type reflective electrode 4025. A connector 4077_{ab} connects the second-p transparent electrode 4035 and the third-p transparent electrode 4045 to the reflective electrode 4025. Accordingly, the anodes of the first LED stack 4023, the second LED stack 4033, and the third LED stack 4043 are commonly connected to the reflective electrode 4025.

[0638] The interconnection line 4075 or 4029 may be disposed to be substantially perpendicular to the reflective electrode 4025 below the reflective electrode 4025, and is connected to the ohmic electrode 4026, thereby being electrically connected to the first conductivity type semiconductor layer 4023_a. The ohmic electrode 4026 is connected to the first conductivity type semiconductor layer 4023_a below the first LED stack 4023. The ohmic electrode 4026 may be disposed outside a lower region of the roughened surface 4043_r of the third LED stack 4043 as illustrated in FIG. 76, and light loss may be thus reduced.

[0639] The connector 4071_a connects the upper surface of the third LED stack 4043 to the interconnection line 4071,

and the connector 4073_a connects the upper surface of the second LED stack 4033 to the interconnection line 4073.

[0640] An upper insulating layer 4081 may be disposed on the interconnection lines 4071 and 4073 and the lower insulating layer 4061 to protect the interconnection lines 4071, 4073, and 4075. The upper insulating layer 4081 may have openings that expose the interconnection lines 4071, 4073, and 4075, and a bonding wire and the like may be connected thereto through the openings.

[0641] According to an exemplary embodiment, the anodes of the first to third LED stacks 4023, 4033, and 4043 are commonly and electrically connected to the reflective electrode 4025, and the cathodes thereof are electrically connected to the interconnection lines 4071, 4073, and 4075, respectively. Accordingly, the first to third LED stacks 4023, 4033, and 4043 may be independently driven. However, the inventive concepts are not limited thereto, and connections of the electrodes and wirings can be variously modified.

[0642] FIGS. 79A to 79H are schematic plan views for describing a method for manufacturing a display apparatus according to an exemplary embodiment. Hereinafter, a method for manufacturing the pixel of FIG. 76 will be described.

[0643] First, the light emitting diode stack 4000 as described with reference to FIG. 72 is prepared.

[0644] Next, referring to FIG. 79A, the roughened surface 4043_r may be formed on the upper surface of the third LED stack 4043. The roughened surface 4043_r may be formed to correspond to each pixel region on the upper surface of the third LED stack 4043. The roughened surface 4043_r may be formed using a chemical etching technique, for example, using a photo-enhanced chemical etch (PEC) technique.

[0645] The roughened surface 4043_r may be partially formed within each pixel region in consideration of a region in which the third LED stack 4043 is to be etched in the future. In particular, the roughened surface 4043_r may be formed so that the ohmic electrode 4026 is disposed outside the roughened surface 4043_r. However, the inventive concepts are limited thereto, and the roughened surface 4043_r may also be formed over substantially the entirety of the upper surface of the third LED stack 4043.

[0646] Referring to FIG. 79B, a peripheral region of the third LED stack 4043 is then etched in each pixel region to expose the third-p transparent electrode 4045. The third LED stack 4043 may be left to have substantially a rectangular or square shape as illustrated, but at least two depression parts may be formed along the edges. In addition, as illustrated, one depression part may be formed to be greater than another depression part.

[0647] Referring to FIG. 79C, the exposed third-p transparent electrode 4045 is then removed except for a portion of the third-p transparent electrode 4045 exposed in a relatively large depression part, to thereby expose the upper surface of the second LED stack 4033. The upper surface of the second LED stack 4033 is exposed around the third LED stack 4043 and is also exposed in another depression part. A region in which the third-p transparent electrode 4045 is exposed and a region in which the second LED stack 4033 is exposed are formed in the relatively large depression part.

[0648] Referring to FIG. 79D, the second LED stack 4033 exposed in the remaining region is removed except for the second LED stack 4033 formed in a relatively small depression part to thereby expose the second-p transparent electrode 4035. The second-p transparent electrode is exposed

around the third LED stack **4043** and the second-p transparent electrode **4035** is also exposed in the relatively large depression part.

[0649] Referring to FIG. 79E, the second-p transparent electrode **4035** exposed around the second LED stack **4043** is then removed except for the second-p transparent electrode **4035** exposed in the relatively large depression part, to thereby expose the upper surface of the first LED stack **4023**.

[0650] Referring to FIG. 79F, the first LED stack **4023** exposed around the third LED stack **4043** continues to be removed and the first insulating layer **4027** is removed to thereby expose the reflective electrode **4025**. Accordingly, the reflective electrode **4025** is exposed around the third LED stack **4043**. The exposed reflective electrode **4025** is patterned so as to have substantially an elongated shape in a vertical direction to thereby form a linear interconnection line. The patterned reflective electrode **4025** is disposed over the plurality of pixel regions in the vertical direction and is spaced apart from a neighboring pixel in a horizontal direction.

[0651] In the illustrated exemplary embodiment, it is described the reflective electrode **4025** is patterned after removing the first LED stack **4023**, but the reflective electrode **4025** may also be formed in advance to have the patterned shape when the reflective electrode **4025** is formed on the substrate **4021**. In this case, it is not necessary to pattern the reflective electrode **4025** after removing the first LED stack **4023**.

[0652] By patterning the reflective electrode **4025**, the second insulating layer **4028** may be exposed. The interconnection line **4029** is disposed to be perpendicular to the reflective electrode **4025**, and is insulated from the reflective electrode **4025** by the second insulating layer **4028**.

[0653] Referring to FIG. 79G, the lower insulating layer **4061** (FIGS. 83 and 84) covering the pixels is then formed. The lower insulating layer **4061** covers the reflective electrode **4025** and covers the side surfaces of the first to third LED stacks **4023**, **4033**, and **4043**. In addition, the lower insulating layer **4061** may at least partially cover the upper surface of the third LED stack **4043**. In a case in which the lower insulating layer **4061** is a transparent layer such as SiO₂, the lower insulating layer **4061** may also cover substantially the entirety of the upper surface of the third LED stack **4043**. Alternatively, the lower insulating layer **4061** may also include a reflective layer or a light absorption layer, and in this case, the lower insulating layer **4061** at least partially exposes the upper surface of the third LED stack **4043** so that light is emitted to the outside.

[0654] The lower insulating layer **4061** may have an opening **4061a** exposing the third LED stack **4043**, an opening **4061b** exposing the second LED stack **4033**, an opening **4061c** exposing the third-p transparent electrode **4045**, an opening **4061d** exposing the second-p transparent electrode **4035**, and an opening **4061e** exposing the reflective electrode **4025**. One or a plurality of openings **4061e** exposing the reflective electrode **4025** may be formed.

[0655] Referring to FIG. 79H, the interconnection lines **4071** and **4073** and the connectors **4071a**, **4073a**, and **77ab** are then formed by a lift-off technique. The interconnection lines **4071** and **4073** are insulated from the reflective electrode **4025** by the lower insulating layer **4061**. The connector **4071a** electrically connects the third LED stack **4043** to the interconnection line **4071** and the connector **4073a**

connects the second LED stack **4033** to the interconnection line **4073**. The connector **77ab** electrically connects the third-p transparent electrode **4045** and the second-p transparent electrode **4035** to the first p-type reflective electrode **4025**.

[0656] The interconnection lines **4071** and **4073** may be disposed to be substantially perpendicular to the reflective electrode **4025** and may connect the plurality of pixels to each other.

[0657] Next, the upper insulating layer **4081** (FIGS. 83 and 84) covers the interconnection lines **4071** and **4073** and the connectors **4071a**, **4073a**, and **4077ab**. The upper insulating layer **4081** may also cover substantially the entirety of the upper surface of the third LED stack **4043**. The upper insulating layer **4081** may be formed of, for example, silicon oxide film or silicon nitride film, and may also include a distribution Bragg reflector. In addition, the upper insulating layer **4081** may include a transparent insulating film and a reflective metal layer, or an organic reflective layer of a multilayer structure thereon to reflect light, or may include a light absorption layer such as black based epoxy to thereby shield light.

[0658] In a case in which the upper insulating layer **4081** reflects or shields light, in order to emit light to the outside, it is necessary to at least partially expose the upper surface of the third LED stack **4043**. Meanwhile, in order to allow an electrical connection from the outside, the upper insulating layer **4081** is partially removed to thereby partially expose the interconnection lines **4071**, **4073**, and **4075**. Further, the upper insulating layer **4081** may also be omitted.

[0659] As the upper insulating layer **4081** is formed, the pixel region illustrated in FIG. 76 is provided. In addition, as illustrated in FIG. 75, the plurality of pixels may be formed on the support substrate **4051**, and those pixels may be connected to each other by the first p-type reflective electrode **4025** and the interconnection lines **4071**, **4073**, and **4075**, and may be driven in a passive matrix manner.

[0660] In the illustrated exemplary embodiment, the method for manufacturing the display apparatus that may be driven in the passive matrix manner is described, but the inventive concepts are not limited thereto, and a display apparatus including the light emitting diode stack illustrated in FIG. 72 may be configured to be driven in various manners.

[0661] For example, it is described that the interconnection lines **4071** and **4073** are formed together on the lower insulating layer **4061**, but the interconnection line **4071** may be formed on the lower insulating layer **4061** and the interconnection line **4073** may also be formed on the upper insulating layer **4081**.

[0662] Meanwhile, in FIG. 72, it is described that the reflective electrode **4025**, the second-p transparent electrode **4035**, and the third-p transparent electrode **4045** are in ohmic contact with the second conductivity type semiconductor layers **4023b**, **4033b**, and **4043b** of the first LED stack **4023**, the second LED stack **4033**, and the third LED stack **4043**, respectively, and it is described that the ohmic electrode **4026** is in ohmic contact with the first conductivity type semiconductor layer **4023a** of the first LED stack **4023**, but the ohmic contact layer is not separately provided to the first conductivity type semiconductor layers **4033a** and **4033b** of the second LED stack **4033** and the third LED stack **4043**. When a size of a pixel is as small as 200 micrometers or less, according to some exemplary embodi-

ments, there is no difficulty in current dispersion even in a case in which a separate ohmic contact layer is not formed in the first conductivity type semiconductor layers **4033a** and **4043a**, which are n-type. However, for current dispersion, transparent electrode layers may be disposed on the n-type semiconductor layers of the second and third LED stacks **4033** and **4043**.

[**0663**] According to exemplary embodiments, the plurality of pixels may be formed at a wafer level by using the light emitting diode stack **4000** for a display, and thus the steps of individually mounting the light emitting diodes may be obviated. Furthermore, since the light emitting diode stack has a structure that the first to third LED stacks **4023**, **4033**, and **4043** are vertically stacked, an area of the sub-pixel may be secured within a limited pixel area. In addition, since light generated in the first LED stack **4023**, the second LED stack **4033**, and the third LED stack **4043** is transmitted through these LED stacks and emitted to the outside, it is possible to reduce light loss.

[**0664**] However, the inventive concepts are not limited thereto, and light emitting devices in which the respective pixels are separated from each other may also be provided, and those light emitting devices are individually mounted on a circuit board, thereby making it possible to provide the display apparatus.

[**0665**] In addition, it is described that the ohmic electrode **4026** is formed on the first conductivity type semiconductor layer **4023a** adjacent to the second conductivity type semiconductor layer **4023b**, but the ohmic electrode **4026** may also be formed on the surface of the first conductivity type semiconductor layer **4023a** opposite to the second conductivity type semiconductor layer **4023b**. In this case, the third LED stack **4043** and the second LED stack **4033** are patterned to expose the ohmic electrode **4026**, and instead of the interconnection line **4029**, a separate interconnection line connecting the ohmic electrode **4026** to the circuit board is provided.

[**0666**] FIG. **80** is a cross-sectional view of a light emitting stacked structure according to an exemplary embodiment.

[**0667**] Referring to FIG. **80**, a light emitting stacked structure according to an exemplary embodiment includes a plurality of sequentially stacked epitaxial stacks. A plurality of epitaxial stacks are provided on the substrate **5010**.

[**0668**] The substrate **5010** has a substantially a plate shape having an upper surface and a lower surface.

[**0669**] A plurality of epitaxial stacks can be mounted on the upper surface of the substrate **5010**, and the substrate **5010** may be provided in various forms. The substrate **5010** may be formed of an insulating material. Examples of the material of the substrate **5010** include glass, quartz, silicon, organic polymer, organic/inorganic composite, or others. However, the material of the substrate **5010** is not limited thereto, and is not particularly limited as long as it has an insulation property. In an exemplary embodiment, the substrate **5010** may further include a wiring part that may provide a light emitting signal and a common voltage to the respective epitaxial stacks. In an exemplary embodiment, in addition to the wiring part, the substrate **5010** may further include a drive element including a thin film transistor, in which case the respective epitaxial stacks may be driven in the active matrix type. To this end, the substrate **5010** may be provided as a printed circuit board **5010** or as a composite

substrate having a wiring part and/or a drive element formed on glass, silicon, quartz, organic polymer, or organic/inorganic composite.

[**0670**] A plurality of epitaxial stacks are sequentially stacked on an upper surface of the substrate **5010**, and respectively emit light.

[**0671**] In an exemplary embodiment, two or more epitaxial stacks may be provided, each emitting light of different wavelength bands from each other. That is, a plurality of epitaxial stacks may be provided, respectively having different energy bands from each other. In an exemplary embodiment, the epitaxial stack on the substrate **5010** is illustrated as being provided with three sequentially stacked layers, including first to third epitaxial stacks **5020**, **5030**, and **5040**.

[**0672**] Each of the epitaxial stacks may emit a color light of a visible light band of various wavelength bands. Light emitted from the lowermost epitaxial stack is a color light of the longest wavelength having the lowest energy band, and the wavelength of the emitted color light becomes shorter in the order from lower to upper sides. The light emitted from the epitaxial stack disposed at the top is a color light of the shortest wavelength having the highest energy band. For example, the first epitaxial stack **5020** may emit the first color light **L1**, the second epitaxial stack **5030** may emit the second color light **L2**, and the third epitaxial stack **5040** may emit the third color light **L3**. The first to third color light **L1**, **L2**, and **L3** correspond to different color light from each other, and the first to third color light **L1**, **L2**, and **L3** may be color light of different wavelength bands from each other which have sequentially decreasing wavelengths. That is, the first to third color light **L1**, **L2**, and **L3** may have different wavelength bands from each other, and the color light may be a shorter wavelength band of a higher energy in an order of the first color light **L1** to the third color light **L3**. However, the inventive concepts are not limited thereto, and when the light emitting stacked structure include micro LEDs, the lowermost epitaxial stack may emit a color of light having any energy band, and the epitaxial stacks disposed thereon may emit a color of light having different energy band than that of the lowermost epitaxial stack due to the small form factor of micro LEDs.

[**0673**] In the exemplary embodiment, the first color light **L1** may be red light, the second color light **L2** may be green light, and the third color light **L3** may be blue light, for example.

[**0674**] Each of the epitaxial stacks emits light to a front direction of the substrate **5010**. In particular, light emitted from one epitaxial stack is passed through another epitaxial stack located in the light path, and travels to the front direction. The front direction may correspond to a direction along which the first to third epitaxial stacks **5020**, **5030** and **5040** are stacked.

[**0675**] Hereinafter, in addition to the front direction and the back direction mentioned above, the “front” direction of the substrate **5010** will be referred to as the “upper” direction, and “back” direction of the substrate **5010** will be referred to as the “lower” direction. Of course, the terms “upper” or “lower” refer to relative directions, which may vary according to the placement and the direction of the light emitting stacked structure.

[**0676**] Each of the epitaxial stacks emits light in an upper direction, and each of the epitaxial stacks transmits most of light emitted from the underlying epitaxial stacks. In par-

ticular, light emitted from the first epitaxial stack **5020** passes through the second epitaxial stack **5030** and the third epitaxial stack **5040** and travels to the front direction, and the light emitted from the second epitaxial stack **5030** passes through the third epitaxial stack **5040** and travels to the front direction. To this end, at least some, or desirably, all of the epitaxial stacks other than the lowermost epitaxial stack may include an optically transmissive material. As used herein, the material being “optically transmissive” not only includes a transparent material that transmits the entire light, but also a material that transmits light of a predetermined wavelength or transmitting a portion of light of a predetermined wavelength. In an exemplary embodiment, each of the epitaxial stacks may transmit about 60% or more of light emitted from the epitaxial stack disposed thereunder, or about 80% or more in another exemplary embodiment, or about 90% or more in yet another exemplary embodiment.

[0677] In the light emitting stacked structure according to an exemplary embodiment, the signal lines for applying emitting signals to the respective epitaxial stacks are independently connected, and accordingly, the respective epitaxial stacks can be independently driven and the light emitting stacked structure can implement various colors according to whether light is emitted from each of the epitaxial stacks. In addition, the epitaxial stacks for emitting light of different wavelengths from each other are overlapped vertically on one another, and thus can be formed in a narrow area.

[0678] FIGS. **81A** and **81B** are cross-sectional views illustrating a light emitting stacked structure according to an exemplary embodiment.

[0679] Referring to FIG. **81A**, in a light emitting stacked structure according to an exemplary embodiment, each of first to third epitaxial stacks **5020**, **5030**, and **5040** may be provided on a substrate **5010** via an adhesive layer or a buffer layer interposed therebetween.

[0680] The adhesive layer **5061** adheres the substrate **5010** and the first epitaxial stack **5020** onto the substrate **5010**. The adhesive layer **5061** may include a conductive or non-conductive material. The adhesive layer **5061** may have conductivity in some areas, when it needs to be electrically connected to the substrate **5010** provided thereunder. The adhesive layer **5061** may include a transparent or opaque material. In an exemplary embodiment, when the substrate **5010** is provided with an opaque material and has a wiring part or the like formed thereon, the adhesive layer **5061** may include an opaque material, for example, a light absorbing material. For the light absorbing material that forms the adhesive layer **5061**, various polymer adhesives may be used, including, for example, an epoxy-based polymer adhesive.

[0681] The buffer layer acts as a component to adhere two adjacent layers to each other, while also serving to relieve the stress or impact between two adjacent layers. The buffer layer is provided between two adjacent epitaxial stacks to adhere the two adjacent epitaxial stacks together, while also serving to relieve the stress or impact that may affect the two adjacent epitaxial stacks.

[0682] The buffer layer includes first and second buffer layers **5063** and **5065**. The first buffer layer **5063** may be provided between the first and second epitaxial stacks **5020** and **5030**, and a second buffer layer **5065** may be provided between the second and third epitaxial stacks **5030** and **5040**.

[0683] The buffer layer includes a material capable of relieving stress or impact, e.g., a material that is capable of absorbing stress or impact when there is stress or impact from the outside. The buffer layer may have a certain elasticity for this purpose. The buffer layer may also include a material having an adhesive force. In addition, the first and second buffer layers **5063** and **5065** may include a non-conductive material and an optically transmissive material. For example, an optically clear adhesive may be used for the first and second buffer layers **5063** and **5065**.

[0684] The material for forming the first and second buffer layers **5063** and **5065** is not particularly limited as long as it is optically transparent and is capable of buffering stress or impact while attaching each of the epitaxial stacks stably. For example, the first and second buffer layers **5063** and **5065** may be formed of an organic material including an epoxy-based polymer such as SU-8, various resists, parylene, poly(methyl methacrylate) (PMMA), benzocyclobutene (BCB), spin on glass (SOG), or others, and inorganic material such as silicon oxide, aluminum oxide, or the like. If necessary, a conductive oxide may also be used as a buffer layer, in which case the conductive oxide should be insulated from other components. When an organic material is used as the buffer layer, the organic material may be applied to the adhesive surface and then bonded at a high temperature and a high pressure in a vacuum state. When an inorganic material is used as the buffer layer, the inorganic material may be deposited on the adhesive surface and then planarized by chemical-mechanical planarization (CMP) or the like, after which the surface is subjected to the plasma treatment and then bonded by bonding under a high vacuum.

[0685] Referring to FIG. **81B**, each of the first and second buffer layers **5063** and **5065** may include an adhesion enhancing layer **5063a** or **5065a** for adhering two epitaxial stacks adjacent to each other, and a shock absorbing layer **5063b** or **5065b** for relieving stress or impact between the two adjacent epitaxial stacks.

[0686] The shock absorbing layer **5063b** and **5065b** between two adjacent epitaxial stacks plays a role of absorbing stress or impact when at least one of the two adjacent epitaxial stacks is exposed to stress or impact.

[0687] The material that forms the shock absorbing layer **5063b** and **5065b** may include, but is not limited to, silicon oxide, silicon nitride, aluminum oxide, or others. In an exemplary embodiment, the shock absorbing layer **5063b** and **5065b** may include silicon oxide.

[0688] In an exemplary embodiment, in addition to stress or impact absorption, the shock absorbing layer **5063b** and **5065b** may have a predetermined adhesion force to adhere two adjacent epitaxial stacks. In particular, the shock absorbing layer **5063b** and **5065b** may include a material with surface energy similar or equivalent to the surface energy of the epitaxial stack to facilitate adhesion to the epitaxial stack. For example, when the surface of the epitaxial stack is imparted with hydrophilicity through a plasma treatment or others, a hydrophilic material such as silicon oxide may be used as the shock absorbing layer in order to improve adhesion to the hydrophilic epitaxial stack.

[0689] The adhesion enhancing layer **5063a** or **5065a** serves to firmly adhere two adjacent epitaxial stacks. Examples of the material for forming the adhesion enhancing layer **5063a** or **5065a** include, but are not limited to, epoxy-based polymers such as SOG, SU-8, various resists, parylene, poly(methyl methacrylate) (PMMA), benzocyc-

clobutene (BCB), or others. In an exemplary embodiment, the adhesion enhancing layer **5063a** or **5065a** may include SOG.

[0690] In an exemplary embodiment, the first buffer layer **5063** may include a first adhesion enhancing layer **5063a** and a first shock absorbing layer **5063b**, and the second buffer layer **5065** may include a second adhesion enhancing layer **5065a** and a second shock absorbing layer **5065b**. In an exemplary embodiment, each of the adhesion enhancing layer and the shock absorbing layer may be provided as one layer, but are not limited thereto, and in another exemplary embodiment, each of the adhesion enhancing layer and the shock absorbing layer may be provided as a plurality of layers.

[0691] In an exemplary embodiment, the order of stacking the adhesion enhancing layer and the shock absorbing layer may be variously changed. For example, the shock absorbing layer may be stacked on the adhesion enhancing layer, or conversely, the adhesion enhancing layer may be stacked on the shock absorbing layer. In addition, the order of stacking the adhesion enhancing layer and the shock absorbing layer in the first buffer layer **5063** and the second buffer layer **5065** may be different. For example, in the first buffer layer **5063**, the first shock absorbing **5063b** layer and the first adhesion enhancing layer **5063a** may be sequentially stacked, while in the second buffer layer **5065**, the first adhesion enhancing layer **5065a** and the second shock absorbing layer **5065b** may be stacked sequentially. FIG. 81B shows an exemplary embodiment where the first shock absorbing layer **5063b** is stacked on the first adhesion enhancing layer **5063a** in the first buffer layer **5063**, and the second shock absorbing layer **5065b** is stacked on the second adhesion enhancing layer **5065a** in the second buffer layer **5065**.

[0692] In an exemplary embodiment, the thicknesses of the first buffer layer **5063** and the second buffer layer **5065** may be substantially the same as each other or different from each other. The thicknesses of the first buffer layer **5063** and the second buffer layer **5065** may be determined in consideration of the amount of impact to the epitaxial stacks in the stacking process of the epitaxial stacks. In an exemplary embodiment, the thickness of the first buffer layer **5063** may be greater than the thickness of the second buffer layer **5065**. In particular, the thickness of the first shock absorbing layer **5063b** in the first buffer layer **5063** may be greater than the thickness of the second shock absorbing layer **5065b** in the second buffer layer **5065**.

[0693] The light emitting stacked structure according to an exemplary embodiment may be manufactured through a process in which the first to third epitaxial stacks **5020**, **5030**, and **5040** are stacked sequentially, and accordingly, the second epitaxial stack **5030** is stacked after the first epitaxial stack **5020** is stacked, and the third epitaxial stack **5040** is stacked after both the first and second epitaxial stacks **5020** and **5030** are stacked. Accordingly, the amount of stress or impact that may be applied to the first epitaxial stack **5020** during a process is greater than the amount of stress or impact that may be applied to the second epitaxial stack **5030**, and with an increased frequency. In particular, since the second epitaxial stack **5030** is stacked in a state that the stack thereunder has a shallow thickness, the second epitaxial stack **5030** is subjected to a greater amount of stress or impact than the stress or impact exerted to the third epitaxial stack **5040** that is stacked on the underlying stack

of a relatively greater thickness. In an exemplary embodiment, the thickness of the first buffer layer **5063** is greater than the thickness of the second buffer layer **5065** to compensate for the difference in stress or impact mentioned above.

[0694] FIG. 82 is a cross-sectional view of a light emitting stacked structure according to an exemplary embodiment.

[0695] Referring to FIG. 82, each of the first to third epitaxial stacks **5020**, **5030**, and **5040** may be provided on the substrate **5010** via the adhesive layer **5061** and the first and second buffer layers **5063** and **5065** interposed therebetween.

[0696] Each of the first to third epitaxial stacks **5020**, **5030**, and **5040** includes p-type semiconductor layers **5025**, **5035**, and **5045**, active layers **5023**, **5033**, and **5043**, and n-type semiconductor layers **5021**, **5031**, and **5041**, which are sequentially disposed.

[0697] The p-type semiconductor layer **5025**, the active layer **5023**, and the n-type semiconductor layer **5021** of the first epitaxial stack **5020** may include a semiconductor material that emits red light.

[0698] Examples of a semiconductor material that emits red light may include aluminum gallium arsenide (AlGaAs), gallium arsenide phosphide (GaAsP), aluminum gallium indium phosphide (AlGaInP), gallium phosphide (GaP), or others. However, the semiconductor material that emits red light is not limited thereto, and various other materials may be used.

[0699] A first p-type contact electrode **5025p** may be provided under the p-type semiconductor layer **5025** of the first epitaxial stack **5020**. The first p-type contact electrode **5025p** of the first epitaxial stack **5020** may be a single layer or a multi-layer metal. For example, the first p-type contact electrode **5025p** may include various materials including metals such as Al, Ti, Cr, Ni, Au, Ag, Ti, Sn, Ni, Cr, W, Cu, or others, or alloys thereof. The first p-type contact electrode **5025p** may include metal having a high reflectivity, and accordingly, since the first p-type contact electrode **5025p** is formed of metal having a high reflectivity, it is possible to increase the emission efficiency of light emitted from the first epitaxial stack **5020** in the upper direction.

[0700] A first n-type contact electrode **5021n** may be provided on an upper portion of the n-type semiconductor layer of the first epitaxial stack **5020**. The first n-type contact electrode **5021n** of the first epitaxial stack **5020** may be a single layer or a multi-layer metal. For example, the first n-type contact electrode **5021n** may be formed of various materials including metals such as Al, Ti, Cr, Ni, Au, Ag, Ti, Sn, Ni, Cr, W, Cu, or others, or alloys thereof. However, the material of the first n-type contact electrode **5021n** is not limited to those mentioned above, and accordingly, other conductive materials may be used.

[0701] The second epitaxial stack **5030** includes an n-type semiconductor layer **5031**, an active layer **5033**, and a p-type semiconductor layer **5035**, which are sequentially disposed. The n-type semiconductor layer **5031**, the active layer **5033**, and the p-type semiconductor layer **5035** may include a semiconductor material that emits green light. Examples of materials for emitting green light include indium gallium nitride (InGaN), gallium nitride (GaN), gallium phosphide (GaP), aluminum gallium indium phosphide (AlGaInP), and aluminum gallium phosphide (AlGaP). However, the semiconductor material that emits green light is not limited thereto, and various other materials may be used.

[0702] A second p-type contact electrode **5035p** is provided under the p-type semiconductor layer **5035** of the second epitaxial stack **5030**. The second p-type contact electrode **5035p** is provided between the first epitaxial stack **5020** and the second epitaxial stack **5030**, or specifically, between the first buffer layer **5063** and the second epitaxial stack **5030**.

[0703] Each of the second p-type contact electrodes **5035p** may include a transparent conductive oxide (TCO). The transparent conductive oxide may include tin oxide (SnO), indium oxide (InO₂), zinc oxide (ZnO), indium tin oxide (ITO), indium tin zinc oxide (ITZO) or others. The transparent conductive compound may be deposited by the chemical vapor deposition (CVD), the physical vapor deposition (PVD), such as an evaporator, a sputter, or others. The second p-type contact electrode **5035p** may be provided with a sufficient thickness to serve as an etch stopper in the fabrication process to be described below, for example, with a thickness of about 5001 angstroms to about 2 micrometers to the extent that the transparency is satisfied.

[0704] The third epitaxial stack **5040** includes a p-type semiconductor layer **5045**, an active layer **5043**, and an n-type semiconductor layer **5041**, which are sequentially disposed. The p-type semiconductor layer **5045**, the active layer **5043**, and the n-type semiconductor layer **5041** may include a semiconductor material that emits blue light. The examples of the materials that emit blue light may include gallium nitride (GaN), indium gallium nitride (InGaN), zinc selenide (ZnSe), or others. However, the semiconductor material that emits blue light is not limited thereto, and various other materials may be used.

[0705] A third p-type contact electrode **5045p** is provided under the p-type semiconductor layer **5045** of the third epitaxial stack **5040**. The third p-type contact electrode **5045p** is provided between the second epitaxial stack **5030** and the third epitaxial stack **5040**, or specifically, between the second buffer layer **5065** and the third epitaxial stack **5040**.

[0706] The second p-type contact electrode **5035p** and the third p-type contact electrode **5045p** between the p-type semiconductor layer **5035** of the second epitaxial stack **5030**, and the p-type semiconductor layer **5045** of the third epitaxial stack **5040** are shared electrodes shared by the second epitaxial stack **5030** and the third epitaxial stack **5040**.

[0707] Since the second p-type contact electrode **5035p** and the third p-type contact electrode **5045p** are at least partially in contact with each other, and physically and electrically connected to each other, when a signal is applied to at least a portion of the second p-type contact electrode **5035p** or the third p-type contact electrode **5045p**, the same signal can be applied to the p-type semiconductor layer **5035** of the second epitaxial stack **5030** and the p-type semiconductor layer **5045** of the third epitaxial stack **5040** at the same time. For example, when a common voltage is applied to one of the second p-type contact electrode **5035p** and the third p-type contact electrode **5045p**, the common voltage is applied to the p-type semiconductor layers of each of the second and third epitaxial stacks **5030** and **5040** through both the second p-type contact electrode **5035p** and the third p-type contact electrode **5045p**.

[0708] In the illustrated exemplary embodiment, although the n-type semiconductor layers **5021**, **5031**, and **5041** and the p-type semiconductor layers **5025**, **5035**, and **5045** of the

first to third epitaxial stacks **5020**, **5030**, and **5040** are each shown as a single layer, these layers may be multilayers and may also include superlattice layers. In addition, the active layers **5023**, **5033**, and **5043** of the first to third epitaxial stacks **5020**, **5030**, and **5040** may include a single quantum well structure or a multi-quantum well structure.

[0709] In an exemplary embodiment, the second and third p-type contact electrodes **5035p** and **5045p**, which are shared electrodes, substantially cover the second and third epitaxial stacks **5030** and **5040**. The second and third p-type contact electrodes **5035p** and **5045p** may include a transparent conductive material to transmit light from the epitaxial stack below. For example, each of the second and third p-type contact electrodes **5035p** and **5045p** may include a transparent conductive oxide (TCO). The transparent conductive oxide may include tin oxide (SnO), indium oxide (InO₂), zinc oxide (ZnO), indium tin oxide (ITO), indium tin zinc oxide (ITZO) or others. The transparent conductive compound may be deposited by the chemical vapor deposition (CVD), the physical vapor deposition (PVD), such as an evaporator, a sputter, or others. The second and third p-type contact electrodes **5035p** and **5045p** may be provided with a sufficient thickness to serve as an etch stopper in the fabrication process to be described below, for example, with a thickness of about 5001 angstroms to about 2 micrometers to the extent that the transparency is satisfied.

[0710] In an exemplary embodiment, common lines may be connected to the first to third p-type contact electrodes **5025p**, **5035p**, and **5045p**. In this case, the common line is a line to which the common voltage is applied. In addition, the light emitting signal lines may be connected to the n-type semiconductor layers **5021**, **5031**, and **5041** of the first to third epitaxial stacks **5020**, **5030**, and **5040**, respectively. A common voltage SC is applied to the first p-type contact electrode **5025p**, the second p-type contact electrode **5035p**, and the third p-type contact electrode **5045p** through the common line, and the light emitting signal is applied to the n-type semiconductor layer **5021** of the first epitaxial stack **5020**, the n-type semiconductor layer **5031** of the second epitaxial stack **5030**, and the n-type semiconductor layer **5041** of the third epitaxial stack **5040** through the light emitting signal line, thereby controlling the light emission of the first to third epitaxial stacks **5020**, **5030**, and **5040**. The light emitting signal includes first to third light emitting signals SR, SG, and SB corresponding to the first to third epitaxial stacks **5020**, **5030**, and **5040**, respectively. In an exemplary embodiment, the first light emitting signal SR may be a signal corresponding to red light, the second light emitting signal SG may be a signal corresponding to green light, and the third light emitting signal SB may be a signal corresponding to an emission of blue light.

[0711] In the illustrated exemplary embodiment described above, it is described that a common voltage is applied to the p-type semiconductor layers **5025**, **5035**, and **5045** of the first to third epitaxial stacks **5020**, **5030**, and **5040**, and the light emitting signal is applied to the n-type semiconductor layers **5021**, **5031**, and **5041** of the first to third epitaxial stacks **5020**, **5030**, and **5040**, but the inventive concepts are not limited thereto. In another exemplary embodiment, a common voltage may be applied to the n-type semiconductor layers **5021**, **5031**, and **5041** of the first to third epitaxial stacks **5020**, **5030**, and **5040**, and light emitting signals may

be applied to the p-type semiconductor layers **5025**, **5035**, and **5045** of the first to third epitaxial stacks **5020**, **5030**, and **5040**.

[0712] In this manner, the first to third epitaxial stacks **5020**, **5030**, and **5040** are driven according to a light emitting signal applied to each of the epitaxial stacks. In particular, the first epitaxial stack **5020** is driven according to a first light emitting signal SR, the second epitaxial stack **5030** is driven according to a second light emitting signal SG, and the third epitaxial stack **5040** is driven according to the third light emitting signal SB. In this case, the first, second, and third driving signals SR, SG, and SB are independently applied to the first to third epitaxial stacks **5020**, **5030**, and **5040**, and as a result, each of the first to third epitaxial stacks **5020**, **5030** and **5040** is independently driven. The light emitting stacked structure may finally provide light of various colors by combining the first to third color light emitted upward from the first to third epitaxial stacks **5020**, **5030**, and **5040**.

[0713] The light emitting stacked structure according to an exemplary embodiment may implement a color in a manner such that portions of different color light are provided on the overlapped region, rather than implementing different color light on different planes spaced apart from each other, thereby advantageously providing compactness and integration of the light emitting element. In a conventional light emitting element, in order to realize full color, light emitting elements that emit different colors, such as red, green, and blue light are generally placed apart from each other on a plane, which would occupy a relatively large area as each of the light emitting elements is arranged on a plane. However, in the light emitting stacked structure according to an exemplary embodiment, it is possible to realize a full color in a remarkably smaller area compared to the conventional light emitting element, by providing a stacked structure having the portions of the light emitting elements that emit different color light overlapped in one region. Accordingly, it is possible to manufacture a high-resolution device even in a small area.

[0714] In addition, the light emitting stacked structure according to an exemplary embodiment significantly reduces defects that may occur during manufacture. In particular, the light emitting stacked structure can be manufactured by stacking in the order of the first to third epitaxial stacks, in which case the second epitaxial stack is stacked in a state that the first epitaxial stack is stacked, and the third epitaxial stack is stacked in a state that both the first and second epitaxial stacks are stacked. However, since the first to third epitaxial stacks are first manufactured on a separate temporary substrate, and then stacked by being transferred onto the substrate, defects may occur during the step of transferring onto the substrate and removing the temporary substrate, the first to third epitaxial stacks and other components on the first to third epitaxial stacks may be exposed to stress or impact. However, since the light emitting stacked structure according to an exemplary embodiment includes a buffer layer, or a stress or shock absorbing layer, between adjacent epitaxial stacks, defects that may occur during processing may be reduced.

[0715] In addition, the conventional light emitting device has a complex structure and thus requires a complicated manufacturing process, particularly when implemented as micro LEDs, which require separately preparing respective as micro LEDs and then forming separate contacts such as

connecting by interconnection lines, or others, for each of the light emitting elements. However, according to an exemplary embodiment, the micro LED stacked structure is to be formed by stacking multi-layers of epitaxial stacks sequentially on a single substrate **5010**, and then forming contacts on the multi-layered epitaxial stacks and connecting by lines through a minimum process. In addition, since micro LEDs of individual colors are separately manufactured and mounted separately, only a single stacked structure is mounted according to an exemplary embodiment, instead of a plurality of light emitting elements. Accordingly, the manufacturing method is simplified significantly.

[0716] The light emitting stacked structure according to an exemplary embodiment may additionally employ various components to provide high purity and color light of high efficiency. For example, a micro LED stacked structure according to an exemplary embodiment may include a wavelength pass filter to block short wavelength light from proceeding toward the epitaxial stack that emits relatively long wavelength light.

[0717] In the following exemplary embodiments, in order to avoid redundant descriptions, differences from the exemplary embodiments described above will be mainly described.

[0718] FIG. **83** is a cross-sectional view of a light emitting stacked structure including a predetermined wavelength pass filter according to an exemplary embodiment.

[0719] Referring to FIG. **83**, a first wavelength pass filter **5071** may be provided between the first epitaxial stack **5020** and the second epitaxial stack **5030** in a light emitting stacked structure according to an exemplary embodiment.

[0720] The first wavelength pass filter **5071** selectively transmits a certain wavelength light, and may transmit a first color light emitted from the first epitaxial stack **5020** while blocks or reflects light other than the first color light. Accordingly, the first color light emitted from the first epitaxial stack **5020** may travel in an upper direction, while the second and third color light emitted from the second and third epitaxial stacks **5030** and **5040** are blocked from traveling toward the first epitaxial stack **5020**, and may be reflected or blocked by the first wavelength pass filter **5071**.

[0721] The second and third color light are high-energy light that may have a relatively shorter wavelength than the first color light, which may additional light emission in the first epitaxial stack **5020** when entering the first epitaxial stack **5020**. In an exemplary embodiment, the second and the third color light may be blocked from entering the first epitaxial stack **5020** by the first wavelength pass filter **5071**.

[0722] In an exemplary embodiment, a second wavelength pass filter **5073** may be provided between the second epitaxial stack **5030** and the third epitaxial stack **5040**. The second wavelength pass filter **5073** transmits the first color light and the second color light emitted from the first and second epitaxial stacks **5020** and **5030**, while blocking or reflecting light other than the first and second color light. Accordingly, the first and second color light emitted from the first and second epitaxial stacks **5020** and **5030** may travel in the upper direction, while the third color light emitted from the third epitaxial stack **5040** is not allowed to travel in a direction toward the first and second epitaxial stacks **5020** and **5030**, but reflected or blocked by the second wavelength pass filter **5073**.

[0723] As described above, the third color light is a relatively high-energy light having a shorter wavelength

than the first and second color light, and when entering the first and second epitaxial stacks **5020** and **5030**, the third color light may induce additional emission in the first and second epitaxial stacks **5020** and **5030**. In an exemplary embodiment, the second wavelength pass filter **5073** prevents the third light from entering the first and second epitaxial stacks **5020** and **5030**.

[**0724**] The first and second wavelength pass filters **5071** and **5073** may be formed in various shapes, and may be formed by alternately stacking insulating films having different refractive indices. For example, the wavelength of transmitted light may be determined by alternately stacking SiO_2 and TiO_2 , and adjusting the thickness and number of stacking of SiO_2 and TiO_2 . The insulating films having different refractive indices may include SiO_2 , TiO_2 , HfO_2 , Nb_2O_5 , ZrO_2 , Ta_2O_5 , or others.

[**0725**] When the first and second wavelength pass filters **5071** and **5073** are formed by stacking inorganic insulating films having different refractive indices from each other, defects due to stress or impact during the manufacturing process, for example, peel-off or cracks may occur. However, according to an exemplary embodiment, such defects may be significantly reduced by providing a buffer layer to relieve the impact.

[**0726**] The light emitting stacked structure according to an exemplary embodiment may additionally employ various components to provide uniform light of high efficiency. For example, a light emitting stacked structure according to an exemplary embodiment may have various irregularities (or roughened surface) on the light exit surface. For example, a light emitting stacked structure according to an exemplary embodiment may have irregularities formed on an upper surface of at least one n-type semiconductor layer of the first to third epitaxial stacks **5020**, **5030**, and **5040**.

[**0727**] In an exemplary embodiment, the irregularities of each of the epitaxial stacks may be selectively formed. For example, irregularities may be provided on the first epitaxial stack **5020**, irregularities may be provided on the first and third epitaxial stacks **5020** and **5040**, or irregularities may be provided on the first to third epitaxial stacks **5020**, **5030** and **5040**. The irregularities of each of the epitaxial stacks may be provided on an n-type semiconductor layer corresponding to the emission surface of each of the epitaxial stacks.

[**0728**] The irregularities are provided to increase light emission efficiency, and may be provided in various forms such as a polygonal pyramid, a hemisphere, or planes with a surface roughness in a random arrangement. The irregularities may be textured through various etching processes or by using a patterned sapphire substrate.

[**0729**] In an exemplary embodiment, the first to third color light from the first to third epitaxial stacks **5020**, **5030**, and **5040** may have different light intensities, and this difference in intensity may lead to differences in visibility. The light emission efficiency may be improved by selectively forming irregularities on the light exit surface of the first to third epitaxial stacks **5020**, **5030** and **5040**, which results in reduction of the visibility differences between the first to third color light. The color light corresponding to red and/or blue color may have lower visibility than the green color, in which case the first epitaxial stack **5020** and/or the third epitaxial stack **5040** may be textured to decrease the difference of visibility. In particular, when the lowermost of the light emitting stacks emits red color light, the light

intensity may be small. As such, the light efficiency may be increased by forming irregularities on the upper surface thereof.

[**0730**] The light emitting stacked structure having the structure described above is a light emitting element capable of expressing various colors, and thus may be employed as a pixel in a display device. In the following exemplary embodiment, a display device will be described as including the light emitting stacked structure according to exemplary embodiments.

[**0731**] FIG. **84** is a plan view of a display device according to an exemplary embodiment, and FIG. **85** is an enlarged plan view illustrating portion P1 of FIG. **84**.

[**0732**] Referring to FIGS. **84** and **85**, the display device **5110** according to an exemplary embodiment may display any visual information such as text, video, photographs, two or three-dimensional images, or others.

[**0733**] The display device **5110** may be provided in various shapes including a closed polygon that includes a straight side, such as a rectangle, or a circle, an ellipse, or the like, that includes a curved side, a semi-circle, or semi-ellipse that includes a combination of straight and curved sides. In an exemplary embodiment, the display device will be described as having substantially a rectangular shape.

[**0734**] The display device **5110** has a plurality of pixels **5110** for displaying images. Each of the pixels **5110** may be a minimum unit for displaying an image. Each pixel **5110** includes the light emitting stacked structure having the structure described above, and may emit white light and/or color light.

[**0735**] In an exemplary embodiment, each pixel includes a first pixel **5110R** that emits red light, a second pixel **5110G** that emits green light, and a third pixel **5110B** that emits blue light. The first to third pixels **5110R**, **5110G**, and **5110B** may correspond to the first to third epitaxial stacks **5020**, **5030**, and **5040** of the light emitting stacked structure described above, respectively.

[**0736**] The pixels **5110** are arranged in a matrix. As used herein, pixels arranged in "a matrix" may not only refer to when the pixels **5110** are arranged in a line along the row or column, but also to when the pixels **5110** are arranged in any repeating pattern, such as generally along the rows and columns, with certain modifications in details, such as the pixels **5110** being arranged in a zigzag shape, for example.

[**0737**] FIG. **86** is a structural diagram of a display device according to an exemplary embodiment.

[**0738**] Referring to FIG. **86**, a display device **5110** according to an exemplary embodiment includes a timing controller **5350**, a scan driver **5310**, a data driver **5330**, a wiring part, and pixels. When the pixels include a plurality of pixels, each of the pixels is individually connected to the scan driver **5310**, the data driver **5330**, or the like through a wiring part.

[**0739**] The timing controller **5350** receives various control signals and image data necessary for driving a display device from outside (e.g., from a system for transmitting image data). The timing controller **5350** rearranges the received image data and transmits the image data to the data driver **5330**. In addition, the timing controller **5350** generates scan control signals and data control signals necessary for driving the scan driver **5310** and the data driver **5330**, and outputs the generated scan control signals and data control signals to the scan driver **5310** and the data driver **5330**.

[0740] The scan driver 5310 receives scan control signals from the timing controller 5350 and generates corresponding scan signals. The data driver 5330 receives data control signals and image data from the timing controller 5350, and generates corresponding data signals.

[0741] The wiring part includes a plurality of signal lines. The wiring part includes scan lines 5130 connecting the scan driver 5310 and the pixels, and data lines 5120 connecting the data driver 5330 and the pixels. The scan lines 5130 may be connected to respective pixels, and accordingly, the scan lines 5130 that correspond to the respective pixels are marked as first to third scan lines 5130R, 5130G, and 5130B (hereinafter, collectively referred to by '5130').

[0742] In addition, the wiring part further includes lines connecting between the timing controller 5350 and the scan driver 5310, the timing controller 5350 and the data driver 5330, or other components, and transmitting the signals.

[0743] The scan lines 5130 provide the scan signals generated at the scan driver 5310 to the pixels. The data signals generated at the data driver 5330 is outputted to the data lines 5120.

[0744] The pixels are connected to the scan lines 5130 and data lines 5120. The pixels selectively emit light in response to the data signals inputted from the data lines 5120 when the scan signals are supplied from scan lines 5130. For example, during each frame period, each of the pixels emits light with the luminance corresponding to the input data signals. The pixels supplied with data signals corresponding to black luminance display black by emitting no light during the corresponding frame period.

[0745] In an exemplary embodiment, the pixels may be driven as either passive or active type. When the display device is driven as the active type, the display device may be supplied with the first and second pixel powers in addition to the scan signals and the data signals.

[0746] FIG. 87 is a circuit diagram of one pixel of a passive type display device. The pixel may be one of R, G, B pixels, and the first pixel 5110R is illustrated as an example. Since the second and third pixels may be driven in substantially the same manner as the first pixel, the circuit diagrams for the second and third pixels will be omitted.

[0747] Referring to FIG. 87, a first pixel 5110R includes a light emitting element 150 connected between a scan line 5130 and a data line 5120. The light emitting element 150 may correspond to the first epitaxial stack 5020. The first epitaxial stack 5020 emits light with a luminance corresponding to a magnitude of the applied voltage when a voltage equal to or greater than a threshold voltage is applied between the p-type semiconductor layer and the n-type semiconductor layer. In particular, the emission of the first pixel 5110R may be controlled by controlling the voltages of the scan signal applied to the first scan line 5130R and/or the data signal applied to the data line 5120.

[0748] FIG. 88 is a circuit diagram of a first pixel of an active type display device.

[0749] When the display device is the active type, the first pixel 5110R may be further supplied with the first and second pixel powers (ELVDD and ELVSS) in addition to the scan signal and the data signal.

[0750] Referring to FIG. 88, the first pixel 5110R includes a light emitting element 150 and a transistor part connected thereto. The light emitting element 150 may correspond to the first epitaxial stack 5020, and the p-type semiconductor layer of the light emitting element 150 may be connected to

the first pixel power ELVDD via the transistor part, and the n-type semiconductor layer may be connected to a second pixel power ELVSS. The first pixel power ELVDD and the second pixel power ELVSS may have different potentials from each other. For example, the second pixel power ELVSS may have potential lower than that of the first pixel power ELVDD, by at least the threshold voltage of the light emitting element. Each of these light emitting elements emits light with a luminance corresponding to the driving current controlled by the transistor part.

[0751] According to an exemplary embodiment, the transistor part includes first and second transistors M1 and M2 and a storage capacitor Cst. However, the inventive concepts are not limited thereto, and the structure of the transistor part may be varied.

[0752] The source electrode of the first transistor M1 (e.g., switching transistor) is connected to the data line 5120, and the drain electrode is connected to the first node N1. Further, the gate electrode of the first transistor is connected to the first scan line 5130R. The first transistor is turned on when a scan signal of a voltage capable of turning on the first transistor M1 is supplied from the first scan line 5130R to the data line 5120, to electrically connect the first node N1. The data signal of the corresponding frame is supplied to the data line 5120, and accordingly, the data signal is transmitted to the first node N1. The data signal transmitted to the first node N1 is charged in the storage capacitor Cst.

[0753] The source electrode of the second transistor M2 is connected to the first pixel power ELVDD, and the drain electrode is connected to the n-type semiconductor layer of the light emitting element. The gate electrode of the second transistor M2 is connected to the first node N1. The second transistor M2 controls an amount of driving current supplied to the light emitting element corresponding to the voltage of the first node N1.

[0754] One electrode of the storage capacitor Cst is connected to the first pixel power ELVDD, and the other electrode is connected to the first node N1. The storage capacitor Cst charges the voltage corresponding to the data signal supplied to the first node N1 and maintains the charged voltage until the data signal of the next frame is supplied.

[0755] FIG. 88 shows a transistor part including two transistors. However, the inventive concepts are not limited thereto, and various modifications are applicable to the structure of the transistor part. For example, the transistor part may include more transistors, capacitors, or the like. In addition, although the specific structures of the first and second transistors, storage capacitors, and lines are not shown, the first and second transistors, storage capacitors, and lines are not particularly limited and can be variously provided.

[0756] The pixels may be implemented in various structures within the scope of the inventive concepts. Hereinafter, a pixel according to an exemplary embodiment will be described with reference to a passive matrix type pixel.

[0757] FIG. 89 is a plan view of a pixel according to an exemplary embodiment, and FIGS. 90A and 90B are cross-sectional views taken along lines I-I' and II-II' of FIG. 89, respectively.

[0758] Referring to FIGS. 89, 90A, and 90B, viewing from a plan view, a pixel according to an exemplary embodiment includes a light emitting region in which a plurality of epitaxial stacks are stacked, and a peripheral region sur-

rounding the light emitting region. The plurality of epitaxial stacks includes first to third epitaxial stacks **5020**, **5030**, and **5040**.

[0759] When viewed from a plan view, the pixel according to an exemplary embodiment has a light emitting region in which a plurality of epitaxial stacks is stacked. At least one side of the light emitting region is provided with a contact for connecting the wiring part to the first to third epitaxial stacks **5020**, **5030**, and **5040**. The contact includes first and second common contacts **5050GC** and **5050BC** for applying a common voltage to the first to third epitaxial stacks **5020**, **5030**, and **5040**, a first contact **5020C** for providing a light emitting signal to the first epitaxial stack **5020**, a second contact **5030C** for providing a light emitting signal to the second epitaxial stack **5030**, and a third contact **5040C** for providing a light emitting signal to the third epitaxial stack **5040**.

[0760] In an exemplary embodiment, the stacked structure may vary depending on the polarity of the semiconductor layers of the first to third epitaxial stacks **5020**, **5030**, and **5040** to which the common voltage is applied. That is, regarding the first and second common contacts **5050GC** and **5050BC**, when there are contact electrodes provided for applying a common voltage to each of the first to third epitaxial stacks **5020**, **5030**, and **5040**, such contact electrodes may be referred to as the “first to third common contact electrodes”, and the first to third contact electrodes may be the “first to third p-type contact electrodes”, respectively, when the common voltage is applied to the p-type semiconductor layer. In an exemplary embodiment where a common voltage is applied to the n-type semiconductor layer, the first to third common contact electrodes may be first to third n-type contact electrodes, respectively. Hereinafter, a common voltage will be described as being applied to a p-type semiconductor layer, and thus, the first to third common contact electrodes will be described as corresponding to first to third p-type contact electrodes, respectively.

[0761] In an exemplary embodiment, when viewed from a plan view, the first and second common contacts **5050GC** and **5050BC** and the first to third contacts **5020C**, **5030C**, and **5040C** may be provided at various positions. For example, when the light emitting stacked structure has substantially a square shape, the first and second common contacts **5050GC** and **5050BC** and the first to third contacts **5020C**, **5030C**, and **5040C** may be disposed in regions corresponding to respective corners of the square. However, the positions of the first and second common contacts **5050GC** and **5050BC** and the first to third contacts **5020C**, **5030C** and **5040C** are not limited thereto, and various modifications are applicable according to the shape of the light emitting stacked structure.

[0762] The plurality of epitaxial stacks includes first to third epitaxial stacks **5020**, **5030**, and **5040**. The first to third epitaxial stacks **5020**, **5030**, and **5040** are connected with first to third light emitting signal lines for providing light emitting signals to each of the first to third epitaxial stacks **5020**, **5030**, and **5040**, and a common line for providing a common voltage to each of the first to third epitaxial stacks **5020**, **5030**, and **5040**. In an exemplary embodiment, the first to third light emitting signal lines may correspond to the first to third scan lines **5130R**, **5130G**, and **5130B**, and the common line may correspond to the data line **5120**. Accordingly, the first to third scan lines **5130R**, **5130G**, and **5130B**

and the data line **5120** are connected to the first to third epitaxial stacks **5020**, **5030**, and **5040**, respectively.

[0763] In an exemplary embodiment, the first to third scan lines **5130R**, **5130G**, and **5130B** may extend substantially in a first direction (e.g., in a transverse direction as shown in the drawing). The data line **5120** may extend substantially in a second direction intersecting with the first to third scan lines **5130R**, **5130G**, and **5130B** (e.g., in a longitudinal direction as shown in the drawing). However, the extending directions of the first to third scan lines **5130R**, **5130G**, and **5130B** and the data line **5120** are not limited thereto, and various modifications are applicable according to the arrangement of the pixels.

[0764] The data line **5120** and the first p-type contact electrode **5025p** extend substantially in a second direction intersecting the first direction, while concurrently providing a common voltage to the p-type semiconductor layer of the first epitaxial stack **5020**. Accordingly, the data line **5120** and the first p-type contact electrode **5025p** may be substantially the same component. Hereinafter, the first p-type contact electrode **5025p** may be referred to as the data line **5120** or vice versa.

[0765] An ohmic electrode **5025p'** for ohmic contact between the first p-type contact electrode **5025p** and the first epitaxial stack **5020** is provided on the light emitting region provided with the first p-type contact electrode **5025p**.

[0766] The first scan line **5130R** is connected to the first epitaxial stack **5020** through the first contact hole CH1, and the data line **5120** is connected via the ohmic electrode **5025p'**. The second scan line **5130G** is connected to the second epitaxial stack **5030** through the second contact hole CH2 and the data line **5120** is connected through the 4ath and 4bth contact holes CH4a and CH4b. The third scan line **5130B** is connected to the third epitaxial stack **5040** through the third contact hole CH3 and the data line **5120** is connected through the 5ath and 5bth contact holes CH5a and CH5b.

[0767] A buffer layer, a contact electrode, a wavelength pass filter, or the like are provided between the substrate **5010** and the first to third epitaxial stacks **5020**, **5030**, and **5040**, respectively. Hereinafter, the pixel according to an exemplary embodiment will be described in the order of stacking.

[0768] According to an exemplary embodiment, a first epitaxial stack **5020** is provided on the substrate **5010** via an adhesive layer **5061** interposed therebetween. In the first epitaxial stack **5020**, a p-type semiconductor layer, an active layer, and an n-type semiconductor layer are sequentially disposed from lower to upper sides.

[0769] A first insulating film **5081** is stacked on a lower surface of the first epitaxial stack **5020**, that is, on the surface facing the substrate **5010**. A plurality of contact holes are formed in the first insulating film **5081**. The contact holes are provided with an ohmic electrode **5025p'** in contact with the p-type semiconductor layer of the first epitaxial stack **5020**. The ohmic electrode **5025p'** may include a variety of materials. In an exemplary embodiment, the ohmic electrode **5025p'** corresponding to the p-type ohmic electrode **5025p'** may include an Au/Zn alloy or an Au/Be alloy. In this case, since the material of the ohmic electrode **5025p'** is lower in reflectivity than Ag, Al, Au, or the like, additional reflective electrodes may be further disposed. As an additional reflective electrode, Ag, Au, or the like may be used, and Ti, Ni, Cr, Ta, or the like may be disposed as an adhesive layer for

adhesion to adjacent components. In this case, the adhesive layer may be thinly deposited on the upper and lower surfaces of the reflective electrode including Ag, Au, or the like.

[0770] The first p-type contact electrode **5025_p** and the data line **5120** are in contact with the ohmic electrode **5025_{p'}**. The first p-type contact electrode **5025_p** (also serving as the data line **5120**) is provided between the first insulating film **5081** and the adhesive layer **5061**.

[0771] When viewed from a plan view, the first p-type contact electrode **5025_p** may be provided in a form such that the first p-type contact electrode **5025_p** overlaps the first epitaxial stack **5020**, or more particularly, overlaps the light emitting region of the first epitaxial stack **5020**, while covering most, or all of the light emitting region. The first p-type contact electrode **5025_p** may include a reflective material so that the first p-type contact electrode **5025_p** may reflect light from the first epitaxial stack **5020**. The first insulating film **81** may also be formed to have a reflective property to facilitate the reflection of light from the first epitaxial stack **5020**. For example, the first insulating film **81** may have an omni-directional reflector (ODR) structure.

[0772] In addition, the material of the first p-type contact electrode layer **5025_p** is selected from metals having high reflectivity to light emitted from the first epitaxial stack **5020**, to maximize the reflectivity of light emitted from the first epitaxial stack **5020**. For example, when the first epitaxial stack **5020** emits red light, metal having a high reflectivity to red light, for example, Au, Al, Ag, or the like may be used as the material of the first p-type contact electrode layer **5025_p**. Au does not have a high reflectivity to light emitted from the second and third epitaxial stacks **5030** and **5040** (e.g., green light and blue light), and thus can reduce a mixture of colors by light emitted from the second and third epitaxial stacks **5030** and **5040**.

[0773] The first wavelength pass filter **5071** and the first n-type contact electrode **5021_n** are provided on an upper surface of the first epitaxial stack **5020**. In an exemplary embodiment, the first n-type contact electrode **5021_n** may include various metals and metal alloys, including Au/Te alloy or Au/Ge alloy, for example.

[0774] The first wavelength pass filter **5071** is provided on the upper surface of the first epitaxial stack **5020** to cover substantially all the light emitting region of the first epitaxial stack **5020**.

[0775] The first n-type contact electrode **5021_n** is provided in a region corresponding to the first contact **5020C** and may include a conductive material. The first wavelength pass filter **5071** is provided with a contact hole through which the first n-type contact electrode **5021_n** is brought into contact with the n-type semiconductor layer on the upper surface of the first epitaxial stack **5020**.

[0776] The first buffer layer **5063** is provided on the first epitaxial stack **5020**, and the second p-type contact electrode **5035_p** and the second epitaxial stack **5030** are sequentially provided on the first buffer layer **5063**. In the second epitaxial stack **5030**, a p-type semiconductor layer, an active layer, and an n-type semiconductor layer are sequentially disposed from lower to upper sides.

[0777] In an exemplary embodiment, the region corresponding to the first contact **5020C** of the second epitaxial stack **5030** is removed, thereby exposing a portion of the upper surface of the first n-type contact electrode **5021_n**. In addition, the second epitaxial stack **5030** may have a smaller

area than the second p-type contact electrode **5035_p**. The region corresponding to the first common contact **550GC** is removed from the second epitaxial stack **5030**, thereby exposing a portion of the upper surface of the second p-type contact electrode **5035_p**.

[0778] The second wavelength pass filter **5073**, the second buffer layer **5065**, and the third p-type contact electrode **5045_p** are sequentially provided on the second epitaxial stack **5030**. The third epitaxial stack **5040** is provided on the third p-type contact electrode **5045_p**. In the third epitaxial stack **5040**, an n-type semiconductor layer, an active layer, and a p-type semiconductor layer are sequentially disposed from lower to upper sides.

[0779] The third epitaxial stack **5040** may have a smaller area than the second epitaxial stack **5030**. The third epitaxial stack **5040** may have a smaller area than the third p-type contact electrode **5045_p**. The region corresponding to the second common contact **5050BC** is removed from the third epitaxial stack **5040**, thereby exposing a portion of the upper surface of the third p-type contact electrode **5045_p**.

[0780] The second insulating film **5083** covering the stacked structure of the first to third epitaxial stacks **5020**, **5030**, and **5040** is provided on the third epitaxial stack **5040**. The second insulating film **5083** may include various organic/inorganic insulating materials, but is not limited thereto. For example, the second insulating film **5083** may include inorganic insulating material including silicon nitride and silicon oxide, or organic insulating material including polyimide.

[0781] The first contact hole CH1 is formed in the second insulating film **5083** to expose an upper surface of the first n-type contact electrode **5021_n** provided in the first contact **5020C**. The first scan line is connected to the first n-type contact electrode **5021_n** through the first contact hole CH1.

[0782] A third insulating film **5085** is provided on the second insulating film **5083**. The third insulating film **5085** may include a material substantially the same as or different from the second insulating film **5083**. The third insulating film **5085** may include various organic/inorganic insulating materials, but is not limited thereto.

[0783] The second and third scan lines **5130G** and **5130B** and the first and second bridge electrodes BR_G and BR_B are provided on the third insulating film **5085**.

[0784] The third insulating film **5085** is provided with a second contact hole CH2 for exposing an upper surface of the second epitaxial stack **5030** at the second contact **5030C**, that is, exposing the n-type semiconductor layer of the second epitaxial stack **5030**, a third contact hole CH3 for exposing an upper surface of the third epitaxial stack **5040** at the third contact **5040C**, that is, exposing an n-type semiconductor layer of the third epitaxial stack **5040**, and 4ath and 4bth contact holes CH4a and CH4b for exposing an upper surface of the first p-type contact electrode **5025_p** and an upper surface of the second p-type contact electrode **5035_p**, at the first common contact **5050GC**, and 5ath and 5bth contact holes CH5a and CH5b for exposing an upper surface of the first p-type contact electrode **5025_p** and an upper surface of the third p-type contact electrode **5045_p**, at the second common contact **5050BC**.

[0785] The second scan line **5130G** is connected to the n-type semiconductor layer of the second epitaxial stack **5030** through the second contact hole CH2. The third scan

line **5130B** is connected to the n-type semiconductor layer of the third epitaxial stack **5040** through the third contact hole **CH3**.

[**0786**] The data line **5120** is connected to the second p-type contact electrode **5035_p** through the **4ath** and **4bth** contact holes **CH4a** and **CH4b** and the first bridge electrode **BR_G**. The data line **5120** is also connected to the third p-type contact electrode **5045_p** through the **5ath** and **5bth** contact holes **CH5a** and **CH5b** and the second bridge electrode **BR_B**.

[**0787**] It is illustrated herein that the second and third scan lines **5130G** and **5130B** in an exemplary embodiment are electrically connected to the n-type semiconductor layer of the second and third epitaxial stacks **5030** and **5040** in direct contact with each other. However, in another exemplary embodiment, the second and third n-type contact electrodes may be further provided between the second and third scan lines **5130G** and **5130B** and the n-type semiconductor layers of the second and third epitaxial stacks **5030** and **5040**.

[**0788**] According to an exemplary embodiment, irregularities may be selectively provided on the upper surfaces of the first to third epitaxial stacks **5020**, **5030**, and **5040**, that is, on an upper surface of the n-type semiconductor of the first to third epitaxial stacks. Each of the irregularities may be provided only at a portion corresponding to the light emitting region, or may be provided over the entire upper surface of the respective semiconductor layers.

[**0789**] In addition, in an exemplary embodiment, a substantially, non-transmissive film may be further provided on sides of the second and/or third insulating films **5083** and **5085** that correspond to the sides of the pixel. The non-transmissive film is a light blocking film that includes a light absorbing or reflective material, which is provided to prevent light from the first to third epitaxial stacks **5020**, **5030**, and **5040** from emerging through the sides of the pixel.

[**0790**] In an exemplary embodiment, the optically non-transmissive film may be formed as a single or multi-layered metal. For example, the optically non-transmissive film may be formed of a variety of materials including metals such as Al, Ti, Cr, Ni, Au, Ag, Ti, Sn, Ni, Cr, W, Cu or others, or alloys thereof.

[**0791**] The optically non-transmissive film may be provided on the side of the second insulating film **5083** as a separate layer formed of a material such as metal or alloy thereof.

[**0792**] The optically non-transmissive film may be provided in such a form that is laterally extending from at least one of the first to third scan lines **5130R**, **5130G**, and **5130B** and the first and second bridge electrodes **BR_G** and **BR_B**. In this case, the optically non-transmissive film extending from one of the first to third scan lines **5130R**, **5130G**, and **5130B** and the first and second bridge electrodes **BR_G** and **BR_B** is provided within a limit such that it is not electrically connected to other conductive components.

[**0793**] In addition, a substantially, non-transmissive film may be provided, which is formed separately from the first to third scan lines **5130R**, **5130G**, and **5130B** and the first and second bridge electrodes **BR_G** and **BR_B**, on the same layer and using substantially the same material during the same process of forming at least one of the first to third scan lines **5130R**, **5130G**, and **5130B** and the first and second bridge electrodes **BR_G** and **BR_B**. In this case, the non-transmissive film may be electrically insulated from the first to third scan lines **5130R**, **5130G**, and **5130B** and the first and second bridge electrodes **BR_G** and **BR_B**.

[**0794**] Alternatively, when no optically non-transmissive film is separately provided, the second and third insulating films **5083** and **5085** may serve as optically non-transmissive films. When the second and third insulating films **5083** and **5085** are used as an optically non-transmissive film, the second and third insulating films **5083** and **5085** may not be provided in a region corresponding to an upper portion (front direction) of the first to third epitaxial stacks **5020**, **5030**, and **5040** to allow light emitted from the first to third epitaxial stacks **5020**, **5030**, and **5040** to travel to the front direction.

[**0795**] The substantially, non-transmissive film is not particularly limited as long as it blocks transmission of light by absorbing or reflecting light. In an exemplary embodiment, the non-transmissive film may be a distributed Bragg reflector (DBR) dielectric mirror, a metal reflective film formed on an insulating film, or an organic polymer film in black color. When a metal reflective film is used as the non-transmissive film, the metal reflective film may be in a floating state that is electrically isolated from the components within other pixels.

[**0796**] By providing the non-transmissive film on the sides of the pixels, it is possible to prevent the phenomenon in which light emitted from a certain pixel affects adjacent pixels, or in which color is mixed with light emitted from the adjacent pixels.

[**0797**] The pixel having the structure described above may be manufactured by sequentially stacking the first to third epitaxial stacks **5020**, **5030**, and **5040** on the substrate **5010** sequentially and patterning the same, which will be described in detail below.

[**0798**] FIGS. **91A** to **91C** are cross-sectional views of line I-I' in FIG. **89**, illustrating a process of stacking first to third epitaxial stacks on a substrate.

[**0799**] Referring to FIG. **91A**, the first epitaxial stack **5020** is formed on the substrate **5010**.

[**0800**] The first epitaxial stack **5020** and the ohmic electrode **5025_p'** are formed on a first temporary substrate **5010_p**. In an exemplary embodiment, the first temporary substrate **5010_p** may be a semiconductor substrate such as a GaAs substrate for forming the first epitaxial stack **5020**. The first epitaxial stack **5020** is fabricated in a manner of stacking the n-type semiconductor layer, the active layer, and the p-type semiconductor layer on the first temporary substrate **5010_p**. The first insulating film **5081** having a contact hole formed thereon is formed on the first temporary substrate **5010_p**, and the ohmic electrode **5025_p'** is formed within the contact hole of the first insulating film **5081**.

[**0801**] The ohmic electrode **5025_p'** is formed by forming the first insulating film **81** on the first temporary substrate **5010_p**, applying photoresist, patterning the photoresist, depositing an ohmic electrode **5025_p'** material on the patterned photoresist, and then lifting off the photoresist pattern. However, the method of forming the ohmic electrode **5025_p'** is not limited thereto. For example, the first insulating film **81** may be formed by forming the first insulating film **81**, patterning the first insulating film **81** by photolithography, forming the ohmic electrode film **5025_p'** with the ohmic electrode film **5025_p'** material and then patterning the ohmic electrode film **5025_p'** by photolithography.

[**0802**] The first p-type contact electrode layer **5025_p** (also serving as the data line **5120**) is formed on the first temporary substrate **5010_p** on which the ohmic electrode **5025_p'** is formed. The first p-type contact electrode layer **5025_p** may

include a reflective material. The first p-type contact electrode layer **5025_p** may be formed by, for example, depositing a metallic material and then patterning the same using photolithography.

[0803] The first epitaxial stack **5020** formed on the first temporary substrate **5010_p** is inverted and attached to the substrate **5010** via the adhesive layer **5061** interposed therebetween.

[0804] After the first epitaxial stack **5020** is attached to the substrate **5010**, the first temporary substrate **5010_p** is removed. The first temporary substrate **5010_p** may be removed by various methods such as wet etching, dry etching, physical removal, laser lift-off, or the like.

[0805] Referring to FIG. 91B, after the first temporary substrate **5010_p** is removed, the first n-type contact electrode **5021_n**, the first wavelength pass filter **5071**, and the first adhesion enhancing layer **5063_a** are formed on the first epitaxial stack **5020**. The first n-type contact electrode **5021_n** may be formed by depositing a conductive material and then patterning by the photolithography process. The first wavelength pass filter **5071** may be formed by alternately stacking insulating films having different refractive indices from each other.

[0806] After the removal of the first temporary substrate **5010_p**, irregularities may be formed on an upper surface (n-type semiconductor layer) of the first epitaxial stack **5020**. The irregularities may be formed by texturing with various etching processes. For example, the irregularities may be formed by various methods such as dry etching using a micro photo process, wet etching using a crystal characteristic, texturing using a physical method such as sand blasting, ion beam etching, texturing based on difference in etching rates of block copolymers, or the like.

[0807] The second epitaxial stack **5030**, the second p-type contact electrode layer **5035_p**, and the first shock absorbing layer **5063_b** are formed on a separate second temporary substrate **5010_q**.

[0808] The second temporary substrate **5010_q** may be a sapphire substrate. The second epitaxial stack **5030** may be fabricated by forming the n-type semiconductor layer, the active layer, and the p-type semiconductor layer on the second temporary substrate **5010_q**.

[0809] The second epitaxial stack **5030** formed on the second temporary substrate **5010_q** is inverted and attached onto the first epitaxial stack **5020**. In this case, the first adhesion enhancing layer **5063_a** and the second shock absorbing layer **5063_b** may be disposed to face each other and then joined. In an exemplary embodiment, the first adhesion enhancing layer **5063_a** and the first shock absorbing layer **5063_b** may include various materials, such as SOG and silicon oxide, respectively.

[0810] After attachment, the second temporary substrate **5010_q** is removed. The second temporary substrate **5010_q** may be removed by various methods such as wet etching, dry etching, physical removal, laser lift-off, or the like.

[0811] According to an exemplary embodiment, in the process of attaching the second epitaxial stack **5030** formed on the second temporary substrate **5010_q** onto the substrate **5010**, and in the process of removing the second temporary substrate **5010_q** from the second epitaxial stack **5030**, the impact applied to the first epitaxial stack **5020**, the second epitaxial stack **5030**, the first wavelength pass filter **5071**, and the second p-type contact electrode **5035_p**, is absorbed and/or relieved by the first buffer layer **5063**, more particu-

larly, by the first shock absorbing layer **5063_b** within the first layer **5063**. This minimizes cracking and peel-off that may otherwise occur in the first epitaxial stack **5020**, the second epitaxial stack **5030**, the first wavelength pass filter **5071**, and the second p-type contact electrode **5035_p**. More particularly, when the first wavelength pass filter **5071** is formed on the upper surface of the first epitaxial stack **5020**, the possibility of having peel-off is remarkably reduced as compared to when the first wavelength pass filter **5071** is formed on the second epitaxial stack **5030** side. When the first wavelength pass filter **5071** is formed on the upper surface of the second epitaxial stack **5030** and then attached to the first epitaxial stack **5020** side, due to impact generated in the process of removing the second temporary substrate **5010_q**, there may be a peel-off defect of the first wavelength pass filter **5071**. However, according to an exemplary embodiment, in addition to the first wavelength pass filter **5071** being formed on the first epitaxial stack **5020** side, the shock absorbing effect by the first shock absorbing layer **5063_b** may prevent the occurrence of defects, such as peel-off.

[0812] Referring to FIG. 91C, the second wavelength pass filter **5073** and the second adhesion enhancing layer **5065_a** are formed on the second epitaxial stack **5030** from which the second temporary substrate **5010_q** has been removed.

[0813] The second wavelength pass filter **5073** may be formed by alternately stacking insulating films having different refractive indices from each other.

[0814] Irregularities may be formed on an upper surface (n-type semiconductor layer) of the second epitaxial stack **5030** after the removal of the second temporary substrate. The irregularities may be textured through various etching processes, or may be formed by using a patterned sapphire substrate for the second temporary substrate.

[0815] The third epitaxial stack **5040**, the third p-type contact electrode layer **5045_p**, and the second shock absorbing layer **5065_b** are formed on a separate third temporary substrate **5010_r**.

[0816] The third temporary substrate **5010_r** may be a sapphire substrate. The third epitaxial stack **5040** may be fabricated by forming the n-type semiconductor layer, the active layer, and the p-type semiconductor layer on the third temporary substrate **5010_r**.

[0817] The third epitaxial stack **5040** formed on the third temporary substrate **5010_r** is inverted and attached onto the second epitaxial stack **5030**. In this case, the second adhesion enhancing layer **5065_a** and the second shock absorbing layer **5065_b** may be disposed to face each other and then joined. In an exemplary embodiment, the second adhesion enhancing layer **5065_a** and the second shock absorbing layer **5065_b** may include various materials, such as SOG and silicon oxide, respectively.

[0818] After attachment, the third temporary substrate **5010_r** is removed. The third temporary substrate **5010_r** may be removed by various methods such as wet etching, dry etching, physical removal, laser lift-off, or the like.

[0819] According to an exemplary embodiment, in the process of attaching the third epitaxial stack **5040** formed on the third temporary substrate **5010_r** onto the substrate **5010**, and in the process of removing the third temporary substrate **5010_r** from the third epitaxial stack **5040**, the impact applied to the second and third epitaxial stacks **5030** and **5040**, the second wavelength pass filter **5073**, and the third p-type contact electrode **5045_p** is absorbed and/or relieved by the

second buffer layer **5065**, in particular, by the second shock absorbing layer **5065b** within the second buffer layer **5065**.

[0820] Accordingly, all of the first to third epitaxial stacks **5020**, **5030**, and **5040** are stacked on the substrate **5010**.

[0821] Irregularities may be formed on an upper surface (n-type semiconductor layer) of the third epitaxial stack **5040** after the removal of the second temporary substrate. The irregularities may be textured through various etching processes or may be formed by using a patterned sapphire substrate for the second temporary substrate **5010q**.

[0822] Hereinafter, a method of manufacturing a pixel by patterning stacked epitaxial stacks according to an exemplary embodiment will be described.

[0823] FIGS. **92**, **94**, **96**, **98**, **100**, **102**, and **104** are plan views sequentially showing a method of manufacturing a pixel on a substrate according to an exemplary embodiment.

[0824] FIGS. **93A**, **93B**, **95A**, **95B**, **97A**, **97B**, **99A**, **99B**, **101A**, **101B**, **103A**, **103B**, **105A**, and **105B** are views taken along line I-I' and line II-II' of corresponding figures, respectively.

[0825] Referring to FIGS. **92**, **93A**, and **93B**, first, the third epitaxial stack **5040** is patterned. Most of the third epitaxial stack **5040** except for the light emitting region is removed and in particular, the portions corresponding to the first and second contacts **5030C** and the first and second common contacts **5050GC** and **5050BC** are removed. The third epitaxial stack **5040** may be removed by various methods such as wet etching or dry etching using photolithography, and the third p-type contact electrode **5045p** may function as an etch stopper.

[0826] Referring to FIGS. **94**, **95A**, and **95B**, the third p-type contact electrode **5045p**, the second buffer layer **5065**, and the second wavelength pass filter **5073** are removed from the region excluding the light emitting region. As such, a portion of the upper surface of the second epitaxial stack **5030** is exposed at the second contact **5030C**.

[0827] The third p-type contact electrode **5045p**, the second buffer layer **5065**, and the second wavelength pass filter **5073** may be removed by various methods such as wet etching or dry etching using photolithography.

[0828] Referring to FIGS. **96**, **97A**, and **97B**, a portion of the second epitaxial stack **5030** is removed, exposing a portion of the upper surface of the second p-type contact electrode **5035p** at the second common contact **5050GC** to the outside. The third p-type contact electrode **5045p** serves as an etch stopper during etching.

[0829] Next, portions of the second p-type contact electrode **5035p**, the first buffer layer **5063**, and the first wavelength pass filter **5071** are etched. Accordingly, the upper surface of the first n-type contact electrode **5021n** is exposed at the first contact **5020C**, and the upper surface of the first epitaxial stack **5020** is exposed at the portions other than the light emitting region.

[0830] The second epitaxial stack **5030**, the second p-type contact electrode **5035p**, the first buffer layer **5063**, and the first wavelength pass filter **5071** may be removed by various methods such as wet etching or dry etching using photolithography.

[0831] Referring to FIGS. **98**, **99A**, and **99B**, the first epitaxial stack **5020** and the first insulating film **5081** are etched in the region excluding the light emitting region. The upper surface of the first p-type contact electrode **5025p** is exposed at the first and second common contacts **5050GC** and **5050BC**.

[0832] Referring to FIGS. **100**, **101A**, and **102B**, the second insulating film **5083** is formed on the front side of the substrate **5010**, and first to third contact holes CH1, CH2, CH3, the 4ath and 4bth contact holes CH4a and CH4b, and the 5ath and 5bth contact holes CH5a and CH5b are formed.

[0833] After deposition, the second insulating film **5083** may be patterned by various methods such as wet etching or dry etching using photolithography.

[0834] Referring to FIGS. **102**, **103A**, and **103B**, the first scan line **5130R** is formed on the patterned second insulating film **5083**. The first scan line **5130R** is connected to the first n-type contact electrode **5021n** through the first contact hole CH1 at the first contact **5020C**.

[0835] The first scan line **5130R** may be formed in various ways. For example, the first scan line **5130R** may be formed by photolithography using a plurality of sheets of masks.

[0836] Next, the third insulating film **5085** is formed on the front side of the substrate **5010**, and the second and third contact holes CH2 and CH3, the 4ath and 4bth contact holes CH4a and CH4b, and the 5ath and 5bth contact holes CH5a and CH5b are formed.

[0837] After deposition, the third insulating film **5085** may be patterned by various methods such as wet etching or dry etching using photolithography.

[0838] Referring to FIGS. **104**, **105A**, and **105B**, the second scan line **5130G**, the third scan line **5130B**, the first bridge electrode BR_G, and the second bridge electrode BR_B are formed on a patterned third insulating film **5085**.

[0839] The second scan line **5130G** is connected to the n-type semiconductor layer of the second epitaxial stack **5030** through the second contact hole CH2 at the second contact **5030C**. The third scan line **5130B** is connected to the n-type semiconductor layer of the fourth epitaxial stack **5040** through a third contact hole CH3 at the third contact **5040C**. The first bridge electrode BR_G is connected to the first p-type contact electrode **5025p** through the 4ath and 4bth contact holes CH4a and CH4b at the first common contact **5050GC**. The second bridge electrode BR_B is connected to the first p-type contact electrode **5025p** through the 5ath and 5bth contact holes CH5a and CH5b at the second common contact **5050BC**.

[0840] The second scan line **5130G**, the third scan line **5130B** and the bridge electrode **5120b** may be formed on the third insulating film **5085** in various ways, for example, by photolithography using a plurality of sheets of masks.

[0841] The second scan line **5130G**, the third scan line **5130B** and the first and second bridge electrodes BR_G and BR_B may be formed by applying photoresist on the substrate **5010** on which the third insulating film **5085** is formed, and then patterning the photoresist, and depositing materials of the second scan line, the third scan line, and the bridge electrode on the patterned photoresist and then lifting off the photoresist pattern.

[0842] According to an exemplary embodiment, the order of forming the first to third scan lines **5130R**, **5130G**, and **5130B** and the first and second bridge electrodes BR_G and BR_B of the wiring part is not particularly limited, and may be formed in various sequences. For example, it is illustrated that the second scan line **5130G**, the third scan line **5130B**, and the first and second bridge electrodes BR_G and BR_B are formed on the third insulating film **5085** in the same stage, but they may be formed in a different order. For example, the first scan line **5130R** and the second scan line **5130G** may be first formed in the same step, followed by the formation of

the additional insulating film and then the third scan line **5130B**. Alternatively, the first scan line **5130R** and the third scan line **5130B** may be formed first in the same step, followed by the formation of the additional insulating film, and then the formation of the second scan line **5130G**. In addition, the first and second bridge electrodes BR_G and BR_B may be formed together at any of the steps of forming the first to third scan lines **5130R**, **5130G**, and **5130B**.

[0843] In addition, in an exemplary embodiment, the positions of the contacts of the respective epitaxial stacks **5020**, **5030**, and **5040** may be formed differently, in which case the positions of the first to third scan lines **5130R**, **5130G**, and **5130B** and the first and second bridge electrodes BR_G and BR_B may also be changed.

[0844] In an exemplary embodiment, an optically non-transmissive film may be further provided on the second insulating film **5083** or the third insulating film **5085**, on the fourth insulating film corresponding to the side of the pixel. The optically non-transmissive film may be formed of a DBR dielectric mirror, a metal reflective film on an insulating film, or an organic polymer film. When a metal reflective film is used as the optically non-transmissive film, it is manufactured in a floating state that is electrically insulated from the components in other pixels. In an exemplary embodiment, the optically non-transmissive film may be formed by depositing two or more insulating films with refractive indices different from each other. For example, the optically non-transmissive film may be formed by stacking a material having a low refractive index and a material having a high refractive index in sequence, or alternatively, formed by alternately stacking insulating films having different refractive indices from each other. Materials having different refractive indices are not particularly limited, but examples thereof include SiO_2 and $SiNx$.

[0845] As described above, in a display device according to an exemplary embodiment, it is possible to sequentially stack a plurality of epitaxial stacks and then form contacts with a wiring part at a plurality of epitaxial stacks at the same time.

[0846] FIG. **106** is a schematic plan view of a display apparatus according to an embodiment, FIG. **107A** is a partial cross-sectional view of FIG. **106**, and FIG. **107B** is a schematic circuit diagram.

[0847] Referring to FIGS. **106** and **107A**, the display apparatus may include a substrate **6021**, a plurality of pixels, a first LED stack **6100**, a second LED stack **6200**, a third LED stack **6300**, an insulating layer (or a buffer layer) **6130** having a multilayer structure, a first color filter **6230**, a second color filter **6330**, a first adhesive layer **6141**, a second adhesive layer **6161**, a third adhesive layer **6261**, and a barrier **6350**. In addition, the display apparatus may include various electrode pads and connectors.

[0848] The substrate **6021** supports semiconductor stacks **6100**, **6200**, and **6300**. Further, the substrate **6021** may have a circuit therein. For example, the substrate **6021** may be a silicon substrate in which thin film transistors are formed therein. TFT substrates are widely used for active matrix driving of a display field, such as in an LCD display field, or the like. Since a configuration of a TFT substrate is well known in the art, detailed descriptions thereof will be omitted. A plurality of pixels may be driven in an active matrix manner, but the inventive concepts are not limited thereto. In another exemplary embodiment, the substrate

6021 may include a passive circuit including data lines and scan lines, and thus, the plurality of pixels may be driven in a passive matrix manner.

[0849] A plurality of pixels may be arranged on the substrate **6021**. The pixels may be spaced apart from each other by a barrier **6350**. The barrier **6350** may be formed of a light reflecting material or a light absorbing material. The barrier **6350** may block light traveling toward a neighboring pixel region by reflection or absorption, thereby preventing light interference between pixels. Examples of the light reflecting material may include a light reflecting material, such as a white photo sensitive solder resistor (PSR), and examples of the light absorbing material may include black epoxy, or others.

[0850] Each pixel includes the first to third LED stacks **6100**, **6200**, and **6300**. The second LED stack **6200** is disposed on the first LED stack **6100** and the third LED stack **6300** is disposed on the second LED stack **6200**.

[0851] The first LED stack **6100** includes an n-type semiconductor layer **6123** and a p-type semiconductor layer **6125**, the second LED stack **6200** includes an n-type semiconductor layer **6223** and a p-type semiconductor layer **6225**, and the third LED stack **6300** includes an n-type semiconductor layer **6323** and a p-type semiconductor layer **6325**. In addition, the first to third LED stacks **6100**, **6200**, and **6300** each include an active layer interposed between the n-type semiconductor layer **6123**, **6223**, or **6323** and the p-type semiconductor layer **6125**, **6225** or **6325**. The active layer may have, in particular, a multiple quantum well structure.

[0852] As an LED stack is positioned closer to the substrate **6021**, the LED stack may emit light with a longer wavelength. For example, the first LED stack **6100** may be an inorganic light emitting diode that emits red light, the second LED stack **6200** may be an inorganic light emitting diode that emits green light, and the third LED stack **6300** may be an inorganic light emitting diode that emits blue light. For example, the first LED stack **6100** may include an AlGaInP-based well layer, the second LED stack **6200** may include an AlGaInP-based or AlGaInN-based well layer, and the third LED stack **6300** may include an AlGaInN-based well layer. However, the inventive concepts are not limited thereto. In particular, when LED stacks include micro LEDs, an LED stack disposed closer to the substrate **6021** may emit light with a shorter wavelength, and LED stacks disposed thereon may emit light with a longer wavelength without adversely affecting operation or requiring color filters due to the small form factor of a micro LED.

[0853] An upper surface of each of the first to third LED stacks **6100**, **6200**, and **6300** may be n-type and a lower surface thereof may be p-type. According to some exemplary embodiments, however, that the semiconductor types of the upper surface and the lower surface of each of the LED stacks may be reversed.

[0854] When the upper surface of the third LED stack **6300** is n-type, the upper surface of the third LED stack **6300** may be surface textured through chemical etching to form a roughened surface (or irregularities). The upper surface of the first LED stack **6100** and the second LED stack **6200** may also be roughened by surface texturing. Meanwhile, when the second LED stack **6200** emits green light, since the green light has higher visibility than the red light or the blue light, it is preferable to increase light emitting efficiency of the first LED stack **6100** and the third LED stack **6300** as

compared to that of the second LED stack **6200**. Thus, surface texturing may be applied to the first LED stack **6100** and the third LED stack **6300** to improve light extraction efficiency, and the second LED stack **6200** may be used without surface texturing to adjust the intensity of red, green, and blue light to similar levels.

[0855] Light generated in the first LED stack **6100** may be transmitted through the second and third LED stacks **6200** and **6300** and emitted to the outside. In addition, since the second LED stack **6200** emits light at a longer wavelength than the third LED stack **6300**, light generated in the second LED stack **6200** may be transmitted through the third LED stack **6300** and emitted to the outside.

[0856] The first color filter **6230** may be disposed between the first LED stack **6100** and the second LED stack **6200**. In addition, the second color filter **6330** may be disposed between the second LED stack **6200** and the third LED stack **6300**. The first color filter **6230** transmits light generated in the first LED stack **6100** and reflects light generated in the second LED stack **6200**. The second color filter **6330** transmits light generated in the first and second LED stacks **6100** and **6200** and reflects light generated in the third LED stack **6300**. Thus, light generated in the first LED stack **6100** may be emitted to the outside through the second LED stack **6200** and the third LED stack **6300**, and light generated in the second LED stack **6200** may be emitted to the outside through the third LED stack **6300**. Further, it is possible to prevent light generated in the second LED stack **6200** from being incident on the first LED stack **6100** and lost, or light generated in the third LED stack **6300** from being incident on the second LED stack **6200** and lost.

[0857] In some exemplary embodiments, the first color filter **6230** may reflect light generated in the third LED stack **6300**.

[0858] The first and second color filters **6230** and **6330** may be, for example, a low pass filter that passes through only a low frequency region, that is, a long wavelength region, a band pass filter that passes through only a predetermined wavelength band, or a band stop filter that blocks only the predetermined wavelength band. In particular, the first and second color filters **6200** and **6300** may be formed by alternately stacking the insulating layers having different refractive indices. For example, the first and second color filters **6200** and **6300** may be formed by alternately stacking TiO_2 and SiO_2 . In particular, the first and second color filters **6200** and **6300** may include a distributed Bragg reflector (DBR). The stop band of the distributed Bragg reflector may be controlled by adjusting a thickness of TiO_2 and SiO_2 . The low pass filter and the band pass filter may also be formed by alternately stacking the insulating layers having different refractive indices.

[0859] The first adhesive layer **6141** is disposed between the substrate **6021** and the first LED stack **6100** and bonds the first LED stack **6100** to the substrate **6021**. The second adhesive layer **6161** is disposed between the first LED stack **6100** and the second LED stack **6200** and bonds the second LED stack **6200** to the first LED stack **6100**. Further, the third adhesive layer **6261** is disposed between the second LED stack **6200** and the third LED stack **6300** and bonds the third LED stack **6300** to the second LED stack **6200**.

[0860] As shown, the second adhesive layer **6161** may be disposed between the first LED stack **6100** and the first color

filter **6230**, and may contact the first color filter **6230**. The second adhesive layer **6161** transmits light generated in the first LED stack **6100**.

[0861] The third adhesive layer **6261** may be disposed between the second LED stack **6200** and the second color filter **6330**, and may contact the second color filter **6330**. The second adhesive layer **6161** transmits light generated in the first LED stack **6100** and the second LED stack **6200**.

[0862] Each of the first to third adhesive layers **6141**, **6161**, and **6261** is formed of an adhesive material that may be patterned. These adhesive layers **6141**, **6161**, and **6261** may include, for example, epoxy, polyimide, SU8, spin-on glass (SOG), benzocyclobutene (BCB), or others, but are not limited thereto.

[0863] A metal bonding material may be disposed in each of the adhesive layers **6141**, **6161**, and **6261**, which is described in more detail below.

[0864] The insulating layer **6130** is disposed between the first adhesive layer **6141** and the first LED stack **6100**. The insulating layer **6130** has a multilayer structure and may include a first insulating layer **6131** in contact with the first LED stack **6100** and a second insulating layer **6135** in contact with the first adhesive layer **6141**. The first insulating layer **6131** may be formed of a silicon nitride film (SiN_x layer), and the second insulating layer **6135** may be formed of a silicon oxide film (SiO_2 layer). Since the silicon nitride film has strong adhesive force to the GaP-based semiconductor layer and the SiO_2 layer has strong adhesive force to the first adhesive layer **6141**, the first LED stack **6100** may be stably fixed on the substrate **6021** by stacking the silicon nitride film and the SiO_2 layer.

[0865] According to an exemplary embodiment, a distributed Bragg reflector may be further disposed between the first insulating layer **6131** and the second insulating layer **6135**. The distributed Bragg reflector prevents light generated in the first LED stack **6100** from being absorbed into the substrate **6021**, thereby improving light efficiency.

[0866] In FIG. 107A, while the first adhesive layer **6141** is shown and described as being divided into each pixel unit by the barrier **6350**, the first adhesive layer **6141** may be continuous over a plurality of pixels in some exemplary embodiments. The insulating layer **6130** may also be continuous over a plurality of pixels.

[0867] The first to third LED stacks **6100**, **6200**, and **6300** may be electrically connected to a circuit in the substrate **6021** using electrode pads, connectors, and ohmic electrodes, and thus, for example, a circuit as shown in FIG. 107B may be implemented. The electrode pads, connectors, and ohmic electrodes are described in more detail below.

[0868] FIG. 107B is a schematic circuit diagram of a display apparatus according to an exemplary embodiment.

[0869] Referring to FIG. 107B, a driving circuit according to an exemplary embodiment may include two or more transistors **Tr1** and **Tr2** and a capacitor. When power supply is connected to selection lines **Vrow1** to **Vrow3** and a data voltage is applied to the data lines **Vdata1** to **Vdata3**, a voltage is applied to the corresponding light emitting diode. Further, charges are charged in the corresponding capacitor in accordance with the values of **Vdata1** to **Vdata3**. A turn-on state of the transistor **Tr2** may be maintained by the charged voltage of the capacitor, and thus even when power is cut off to the selection line **Vrow1**, voltage of the capacitor may be maintained and the voltage may be applied to the light emitting diodes **LED1** to **LED3**. Further, currents flowing

through the LED1 to the LED3 may be changed according to values of Vdata1 to Vdata3. The current may always be supplied through Vdd, and thus, continuous light emission is possible.

[0870] The transistors Tr1 and Tr2 and the capacitor may be formed in the substrate 6021. Here, the light emitting diodes LED1 to LED3 may correspond to the first to third LED stacks 6100, 6200 and 6300 stacked in one pixel, respectively. Anodes of the first to third LED stacks 6100, 6200 and 6300 are connected to the transistor Tr2, and cathodes thereof are grounded. The first to third LED stacks 6100, 6200, and 6300 may be electrically grounded in common.

[0871] FIG. 107B exemplarily shows for a circuit diagram for an active matrix driving, but other circuits for the active matrix driving may be used. In addition, according to an exemplary embodiment, passive matrix driving may also be implemented.

[0872] Hereinafter, a manufacturing method of a display apparatus will be described in detail.

[0873] FIGS. 108A to 114 are schematic plan views and cross-sectional views illustrating a method of manufacturing a display apparatus according to an exemplary embodiment. In each of the drawings, the cross-sectional view is taken along line shown in the corresponding plan view.

[0874] First, referring to FIG. 108A, the first LED stack 6100 is grown on the first substrate 6121. The first substrate 6121 may be, for example, a GaAs substrate. The first LED stack 6100 is formed of AlGaInP-based semiconductor layers, and includes an n-type semiconductor layer 6123, an active layer, and a p-type semiconductor layer 6125. The first LED stack 6100 may have, for example, a composition of Al, Ga, and In to emit red light.

[0875] The p-type semiconductor layer 6125 and the active layer are etched to expose the n-type semiconductor layer 6123. The p-type semiconductor layer 6125 and the active layer may be patterned using photolithography and etching techniques. In FIG. 108A, although a portion corresponding to one pixel region is shown, the first LED stack 6100 may be formed over the plurality of pixel regions on the substrate 6121, and the n-type semiconductor layer 6123 will be exposed corresponding to each pixel region.

[0876] Referring to FIG. 108B, ohmic contact layers 6127 and 6129 are formed. The ohmic contact layers 6127 and 6129 may be formed for each pixel region. The ohmic contact layer 6127 is in ohmic contact with the n-type semiconductor layer 6123, and the ohmic contact layer 6129 is in ohmic contact with the p-type semiconductor layer 6125. For example, the ohmic contact layer 6127 may include AuTe or AuGe, and the ohmic contact layer 6129 may include AuBe or AuZn.

[0877] Referring to FIG. 108C, an insulating layer 6130 is formed on the first LED stack 6100. The insulating layer 6130 has a multilayer structure and is patterned to have openings that expose the ohmic contact layers 6127 and 6129. The insulating layer 6130 may include a first insulating layer 6131 and a second insulating layer 6135, and may also include a distributed Bragg reflector 6133. The second insulating layer 6135 may be incorporated into the distributed Bragg reflector 6133 as a part of the distributed Bragg reflector 6133.

[0878] The first insulating layer 6131 may include, for example, a silicon nitride film, and the second insulating layer 6135 may include a silicon oxide film. The silicon

nitride film exhibits good adhesion properties to the AlGaInP-based semiconductor layer, but the silicon oxide film has poor adhesion properties to the AlGaInP-based semiconductor layer. The silicon oxide film has good adhesion to the first adhesive layer 6141, which will be described below, while the silicon nitride film has poor adhesion properties to the first adhesive layer 6141. Since the silicon nitride film and the silicon oxide film exhibit mutually complementary stress characteristics, it is possible to improve process stability by using the silicon nitride film and the silicon oxide film together, thereby preventing occurrence of defects.

[0879] While the ohmic contact layers 6127 and 6129 are described as being formed first, and the insulating layer 6130 is formed thereafter, according to some exemplary embodiments, the insulating layer 6130 may be formed first, and the ohmic contact layers 6127 and 6129 may be formed in the openings of the insulating layer 6130 that expose the n-type semiconductor layer 6123 and the p-type semiconductor layer 6125.

[0880] Referring to FIG. 108D, subsequently, first electrode pads 6137, 6138, 6139, and 6140 are formed. The first electrode pads 6137 and 6139 are connected to the ohmic contact layers 6127 and 6129 through the openings of the insulating layer 6130, respectively. The first electrode pads 6138 and 6140 are disposed on the insulating layer 6130 and are insulated from the first LED stack 6100. As described below, the first electrode pads 6138 and 6140 will be electrically connected to the p-type semiconductor layers 6225 and 6325 of the second LED stack 6200 and the third LED stack 6300, respectively. The first electrode pads 6137, 6138, 6139, and 6140 may have a multilayer structure, and particularly, may include a barrier metal layer on an upper surface thereof.

[0881] Referring to FIG. 108E, a first adhesive layer 6141 is then formed on the first electrode pads 6137, 6138, 6139, and 6140. The first adhesive layer 6141 may contact the second insulating layer 6135.

[0882] The first adhesive layer 6141 is patterned to have openings that expose the first electrode pads 6137, 6138, 6139, and 6140. As such, the first adhesive layer 6141 is formed of a material that may be patterned, and may be formed of, for example, epoxy, polyimide, SU8, SOG, BCB, or others.

[0883] Metal bonding materials 6143 having substantially a ball shape are formed in the openings of the first adhesive layer 6141. The metal bonding material 6143 may be formed of, for example, an indium ball or a solder ball, such as AuSn, Sn, or the like. The metal bonding materials 6143 having substantially a ball shape may have substantially the same height as a surface of the first adhesive layer 6141 or higher height than the surface of the first adhesive layer 6141. However, a volume of each metal bonding material may be smaller than a volume of the opening in the first adhesive layer 6141.

[0884] Referring to FIG. 109A, subsequently, the substrate 6021 and the first LED stack 6100 are bonded. The electrode pads 6027, 6028, 6029 and 6030 are disposed on the substrate 6021 in correspondence with the first electrode pads 6137, 6138, 6139 and 6140, and the metal bonding materials 6143 bond the first electrode pads 6137, 6138, 6139, and 6140 with the electrode pads 6027, 6028, 6029, and 6030. Further, the first adhesive layer 6141 bonds the substrate 6021 and the insulating layer 6130.

[0885] The substrate 6021 may be a glass substrate on which a thin film transistor is formed, a Si substrate on which a CMOS transistor is formed, or others, for active matrix driving.

[0886] While the first electrode pads 6137 and 6139 are shown as being spaced apart from the ohmic contact layers 6127 and 6129, the first electrode pads 6137 and 6139 are electrically connected to the ohmic contact layers 6127 and 6129 through the insulating layer 6130, respectively.

[0887] Although the first adhesive layer 6141 and the metal bonding materials 6143 are described as being formed at the first substrate 6121 side, the first adhesive layer 6141 and the metal bonding materials 6143 may be formed at the substrate 6021 side, or adhesive layers may be formed at the first substrate 6121 side and the substrate 6021 side, respectively, and these adhesive layers may be bonded to each other.

[0888] The metal bonding materials 6143 are pressed by these pads between the first electrode pads 6137, 6138, 6139, and 6140, and the electrode pads 6027, 6028, 6029, and 6030 on the substrate 6021, and thus, upper and lower surfaces are deformed to have a flat shape according to the shape of the electrode pads. Since the metal bonding materials 6143 are deformed in the openings of the first adhesive layer 6141, the metal bonding materials 6143 may substantially completely fill the openings of the first adhesive layer 6141 to be in close contact with the first adhesive layer 6141, or an empty space may be formed in the openings of the first adhesive layer 6141. The first adhesive layer 6141 may contract in a vertical direction and may expand in a horizontal direction under heating and pressurizing condition, and thus a shape of an inner wall of the openings may be deformed.

[0889] The shapes of the metal bonding members 6143 and the first adhesive layer 6141 are described below with reference to FIGS. 115A, 115B, and 115C.

[0890] Referring to FIG. 109B, the first substrate 6121 is removed, and the n-type semiconductor layer 6123 is exposed. The first substrate 6121 may be removed using a wet etching technique or the like. A surface roughened by surface texturing may be formed on the surface of the exposed n-type semiconductor layer 6123.

[0891] Referring to FIG. 109C, holes H1 passing through the first LED stack 6100 and the insulating layer 6130 may be formed using a hard mask or the like. The holes H1 may expose the first electrode pads 6137, 6138, and 6140, respectively. The hole H1 is not formed on the first electrode pad 6139, and thus the first electrode pad 6139 is not exposed through the first LED stack 6100.

[0892] Then, an insulating layer 6153 is formed to cover the surface of the first LED stack 6100 and side walls of the holes H1. The insulating layer 6153 is patterned to expose the first electrode pads 6137, 6138, 6139, and 6140 in the holes H1. The insulating layer 6153 may include a silicon nitride film or a silicon oxide film.

[0893] Referring to FIG. 109D, first connectors 6157, 6158, and 6160 that are electrically connected to the first electrode pads 6137, 6138, and 6140 through the holes H1, respectively, are formed.

[0894] The first-1 connector 6157 is connected to the first electrode pad 6137, the first-2 connector 6158 is connected to the first electrode pad 6138, and the first-3 connector 6160 is connected to the first electrode pad 6140. The first electrode pad 6140 is electrically connected to the n-type

semiconductor layer 6123 of the first LED stack 6100, and thus the first connector 6157 is also electrically connected to the n-type semiconductor layer 6123. The first-2 connector 6158 and the first-3 connector 6160 are electrically insulated from the first LED stack 6100.

[0895] Referring to FIG. 109E, a second adhesive layer 6161 is then formed on the first connectors 6157, 6158, and 6160. The second adhesive layer 6161 may contact the insulating layer 6153.

[0896] The second adhesive layer 6161 is patterned to have openings that expose the first connectors 6157, 6158, and 6160. As such, the second adhesive layer 6161 is formed of a material that may be patterned similarly to the first adhesive layer 6141, and may be formed of, for example, epoxy, polyimide, SU8, SOG, BCB, or others.

[0897] Metal bonding materials 6163 having substantially a ball shape are formed in the openings of the second adhesive layer 6161. The material and shape of the metal bonding material 6163 are similar to those of the metal bonding material 6143 described above, and thus, detailed descriptions thereof are omitted.

[0898] Referring to FIG. 110A, the second LED stack 6200 is grown on a second substrate 6221, and a second transparent electrode 6229 is formed on the second LED stack 6200.

[0899] The second substrate 6221 may be a substrate capable of growing the second LED stack 6200, for example, a sapphire substrate or a GaAs substrate.

[0900] The second LED stack 6200 may be formed of AlGaInP-based semiconductor layers or AlGaInN-based semiconductor layers. The second LED stack 6200 may include an n-type semiconductor layer 6223, a p-type semiconductor layer 6225, and an active layer, and the active layer may have a multiple quantum well structure. A composition ratio of the well layer in the active layer may be determined so that the second LED stack 6200 emits green light, for example.

[0901] The second transparent electrode 6229 is in ohmic contact with the p-type semiconductor layer. The second transparent electrode 6229 may be formed of a metal layer or a conductive oxide layer which is transparent to red light and green light. Examples of the conductive oxide layer may include SnO₂, InO₂, ITO, ZnO, IZO, or others.

[0902] Referring to FIG. 110B, the second transparent electrode 6229, the p-type semiconductor layer 6225, and the active layer are patterned to partially expose the n-type semiconductor layer 6223. The n-type semiconductor layer 6223 will be exposed in a plurality of regions corresponding to a plurality of pixel regions on the second substrate 6221.

[0903] Although the n-type semiconductor layer 6223 is described as being exposed after the second transparent electrode 6229 is formed, in some exemplary embodiments, the n-type semiconductor layer 6223 may be exposed first and the second transparent electrode 6229 may be formed thereafter.

[0904] Referring to FIG. 110C, a first color filter 6230 is formed on the second transparent electrode 6229. The first color filter 6230 is formed to transmit light generated in the first LED stack 6100 and to reflect light generated in the second LED stack 6200.

[0905] Then, an insulating layer 6231 may be formed on the first color filter 6230. The insulating layer 6231 may be formed to control stress and may be formed of, for example,

a silicon nitride film (SiN_x) or a silicon oxide film (SiO_2). The insulating layer **6231** may be formed first before the first color filter **6230** is formed.

[0906] Openings exposing the n-type semiconductor layer **6223** and the second transparent electrode **6229** are formed by patterning the insulating layer **6231** and the first color filter **6230**.

[0907] Although the first color filter **6230** is described as being formed after the n-type semiconductor layer **6223** is exposed, according to some exemplary embodiments, the first color filter **6230** may be formed first, and then, the first color filter **6230**, the second transparent electrode **6229**, the p-type semiconductor layer **6225**, and the active layer may be patterned to expose the n-type semiconductor layer **6223**. Then, the insulating layer **6231** may be formed to cover side surfaces of the p-type semiconductor layer **6225** and the active layer.

[0908] Referring to FIG. **110D**, subsequently, the second electrode pads **6237**, **6238**, and **6240** are formed on the first color filter **6230** or the insulating layer **6231**. The second electrode pad **6237** may be electrically connected to the n-type semiconductor layer **6223** through the opening of the first color filter **6230**, and the second electrode pad **6238** may be electrically connected to the second transparent electrode **6229** through the opening of the first color filter **6230**. The second electrode pad **6240** is disposed on the first color filter **6240** and is insulated from the second LED stack **6200**.

[0909] Referring to FIG. **111A**, the second LED stack **6200** and the second electrode pads **6237**, **6238**, and **6240** that are described with reference to FIG. **110D**, are coupled on the second adhesive layer **6161** and the metal bonding materials **6163** that are described with reference to FIG. **109E**. The metal bonding materials **6163** may bond the first connectors **6157**, **6158**, and **6160** and the second electrode pads **6237**, **6238**, and **6240**, respectively, and the second adhesive layer **6161** may bond the insulating layer **6231** and the insulating layer **6153**. The bonding using the second adhesive layer **6161** and the metal bonding materials **6163** is similar to that described with reference to FIG. **109A**, and thus, detailed description thereof are omitted.

[0910] The second substrate **6221** is separated from the second LED stack **6200**, and the surface of the second LED stack **6200** is exposed. The second substrate **6221** may be separated using a technique such as etching, laser lift-off, or the like. A surface roughened by surface texturing may be formed on the surface of the exposed second LED stack **6200**, that is, the surface of the n-type semiconductor layer **6223**.

[0911] Although the second adhesive layer **6161** and the metal bonding materials **6163** are described as being formed on the first LED stack **6100** to bond the second LED stack **6200**, according to some exemplary embodiments, the second adhesive layer **6161** and the metal bonding materials **6163** may be formed at the second LED stack **6200** side. Further, an adhesive layer may be formed on the first LED stack **6100** and the second LED stack **6200**, respectively, and these adhesive layers may be bonded to each other.

[0912] Referring to FIG. **111B**, holes **H2** passing through the second LED stack **6200**, the second transparent electrode **6229**, the first color filter **6230**, and the insulating layer **6231** may be formed using a hard mask or the like. The holes **H2** may expose the second electrode pads **6237** and **6240**, respectively. The hole **H2** is not formed on the second

electrode pad **238**, and thus, the second electrode pad **238** is not exposed through the second LED stack **6200**.

[0913] Then, an insulating layer **6253** is formed to cover the surface of the second LED stack **6200** and side walls of the holes **H2**. The insulating layer **6253** is patterned to expose the second electrode pads **6237** and **6240** in the holes **H2**. The insulating layer **6253** may include a silicon nitride film or a silicon oxide film.

[0914] Referring to FIG. **111C**, second connectors **6257** and **6260** that are electrically connected to the second electrode pads **6237** and **6240** through the holes **H2**, respectively, are formed. The second-1 connector **6257** is connected to the second electrode pad **6237** and thus electrically connected to the n-type semiconductor layer **6223**. The second-2 connector **6260** is insulated from the second LED stack **6200** and insulated from the first LED stack **6100**.

[0915] Further, the second-1 connector **6257** is electrically connected to the electrode pad **6027** through the first-1 connector **6157**, and the second-2 connector **6260** is electrically connected to the electrode pad **6030** through the first-3 connector **6160**. The second-1 connector **6257** may be stacked in a vertical direction to the first-1 connector **6157**, and the second-2 connector **6260** may be stacked in a vertical direction to the first-3 connector **6160**. However, the inventive concepts are not limited thereto.

[0916] Referring to FIG. **111D**, a third adhesive layer **6261** is then formed on the second connectors **6257** and **6260**. The third adhesive layer **6261** may contact the insulating layer **6253**.

[0917] The third adhesive layer **6261** is patterned to have openings that expose the second connectors **6257** and **6260**. As such, the third adhesive layer **6261** is formed of a material that may be patterned similarly to the first adhesive layer **6141**, and may be formed of, for example, epoxy, polyimide, SU8, SOG, BCB, or others.

[0918] Metal bonding materials **6263** having substantially a ball shape are formed in the openings of the third adhesive layer **6261**. The material and shape of the metal bonding material **6263** are similar to those of the metal bonding material **6143** described above, and thus, detailed descriptions thereof are omitted.

[0919] Referring to FIG. **112A**, the third LED stack **6300** is grown on a third substrate **6321**, and a third transparent electrode **6329** is formed on the third LED stack **6300**.

[0920] The third substrate **6321** may be a substrate capable of growing the third LED stack **6300**, for example, a sapphire substrate. The third LED stack **6300** may be formed of AlGaInN-based semiconductor layers. The third LED stack **6300** may include an n-type semiconductor layer **6323**, a p-type semiconductor layer **6325**, and an active layer, and the active layer may have a multiple quantum well structure. A composition ratio of the well layer in the active layer may be determined so that the third LED stack **6300** emits blue light, for example.

[0921] The third transparent electrode **6329** is in ohmic contact with the p-type semiconductor layer **6325**. The third transparent electrode **6329** may be formed of a metal layer or a conductive oxide layer which is transparent to red light, green light, and blue light. Examples of the conductive oxide layer may include SnO_2 , InO_2 , ITO, ZnO, IZO, or others.

[0922] Referring to FIG. **112B**, the third transparent electrode **6329**, the p-type semiconductor layer **6325**, and the active layer are patterned to partially expose the n-type semiconductor layer **6323**. The n-type semiconductor layer

6323 will be exposed in a plurality of regions corresponding to a plurality of pixel regions on the third substrate **6321**.

[0923] Although the n-type semiconductor layer **6323** is described as being exposed after the third transparent electrode **6329** is formed, according to some exemplary embodiments, the n-type semiconductor layer **6323** may be exposed before the first and the third transparent electrode **6329** may be formed.

[0924] Referring to FIG. 112C, a second color filter **6330** is formed on the third transparent electrode **6329**. The second color filter **6330** is formed to transmit light generated in the first LED stack **6100** and the second LED stack **6200**, and to reflect light generated in the third LED stack **6300**.

[0925] Then, an insulating layer **6331** may be formed on the second color filter **6330**. The insulating layer **6331** may be formed to control stress and may be formed of, for example, a silicon nitride film (SiN_x) or a silicon oxide film (SiO₂). The insulating layer **6331** may be formed first before the second color filter **6330** is formed. Meanwhile, openings exposing the n-type semiconductor layer **6323** and the second transparent electrode **6329** are formed by patterning the insulating layer **6331** and the second color filter **6330**.

[0926] Although the second color filter **6330** is described as being formed after the n-type semiconductor layer **6323** is exposed, according to some exemplary embodiments, the second color filter **6330** may be formed first, and the second color filter **6330**, the third transparent electrode **6329**, the p-type semiconductor layer **6325**, and the active layer may be patterned to expose the n-type semiconductor layer **6323** thereafter. Then, the insulating layer **6331** may be formed to cover side surfaces of the p-type semiconductor layer **6325** and the active layer.

[0927] Referring to FIG. 112D, subsequently, the third electrode pads **6337** and **6340** are formed on the second color filter **6330** or the insulating layer **6331**. The third electrode pad **6337** may be electrically connected to the n-type semiconductor layer **6323** through the opening of the second color filter **6330**, and the third electrode pad **6340** may be electrically connected to the third transparent electrode **6329** through the opening of the second color filter **6330**.

[0928] Referring to FIG. 113A, the third LED stack **6300** and the third electrode pads **6337** and **6340** that are described with reference to FIG. 112D, are coupled to the third adhesive layer **6261** by the metal bonding materials **6263** that are described with reference to FIG. 111E. The metal bonding materials **6263** may bond the second connectors **6257** and **6260** and the third electrode pads **6337** and **6340**, respectively, and the third adhesive layer **6261** may bond the insulating layer **6331** and the insulating layer **6253**. The bonding using the third adhesive layer **6261** and the metal bonding materials **6263** is similar to that described with reference to FIG. 109A, and thus, detailed descriptions thereof are omitted.

[0929] The third substrate **6321** is separated from the third LED stack **6300**, and the surface of the third LED stack **6300** is exposed. The third substrate **6321** may be separated using a technique such as laser lift-off, chemical lift-off, or others. A surface roughened by surface texturing may be formed on the surface of the exposed third LED stack **6300**, that is, the surface of the n-type semiconductor layer **6323**.

[0930] Although the third adhesive layer **6261** and the metal bonding materials **6263** are described as being formed on the second LED stack **6200** to bond the third LED stack

6300, according to some exemplary embodiments, the third adhesive layer **6261** and the metal bonding materials **6263** may be formed at the third LED stack **6300** side. Further, an adhesive layer may be formed on the second LED stack **6200** and the third LED stack **6300**, respectively, and these adhesive layers may be bonded to each other.

[0931] Referring to FIG. 113B, subsequently, regions between adjacent pixels are then etched to separate the pixels, and an insulating layer **6341** may be formed. The insulating layer **6341** may cover a side surface and an upper surface of each pixel. A region between adjacent pixels may be removed to expose the substrate **6021**, but the inventive concepts are not limited thereto. For example, the first adhesive layer **6141** may be formed continuously over a plurality of pixel regions without being separated, and the insulating layer **6130** may also be continuous.

[0932] Referring to FIG. 114, subsequently, a barrier **6350** may be formed in a separation region between the pixel regions. The barrier **6350** may be formed of a light reflecting layer or a light absorbing layer, and thus light interference between pixels may be prevented. The light reflecting layer may include, for example, a white PSR, a distributed Bragg reflector, an insulating layer such as SiO₂, and a reflective metal layer deposited thereon, or a highly reflective organic layer. For a light blocking layer, black epoxy, for example, may be used.

[0933] Thus, a display apparatus according to an exemplary embodiment, in which a plurality of pixels are arranged on the substrate **6021**, may be provided. The first to third LED stacks **6100**, **6200**, and **6300** in each pixel may be independently driven by power input through the electrode pads **6027**, **6028**, **6029**, and **6030**.

[0934] FIGS. 115A, 115B, and 115C are schematic cross-sectional views of the metal bonding materials **6143**, **6163**, and **6263**.

[0935] Referring to FIG. 115A, the metal bonding materials **6143**, **6163**, and **6263** are disposed in the openings in the first to third adhesive layers **6141**, **6161**, and **6261**. A lower surface of the metal bonding materials **6143**, **6163**, and **6263** is in contact with the electrode pads **6030** or the connector **6160** or **6260**, and thus, the metal bonding materials **6143**, **6163**, and **6263** may have a substantially flat shape depending on an upper surface shape of the electrode pads or connectors. The upper surfaces of the metal bonding materials **6143**, **6163**, and **6263** may have substantially a flat shape depending on the shape of the electrode pads **6140**, **6240**, and **6340**. A side surface of the metal bonding materials **6143**, **6163**, and **6263** may have a substantially curved shape. A central portion of the metal bonding materials **6143**, **6163**, and **6263** may have a convex shape to the outside.

[0936] An inner wall of the openings of the adhesive layers **6141**, **6161**, and **6261** may also have substantially a convex shape inward of the openings, and side surfaces of the metal bonding materials **6143**, **6163** and **6263** may be in contact with side surfaces of the adhesive layers **6141**, **6161** and **6261**. However, if volume of the metal bonding materials **6143**, **6163**, and **6263** is less than volume of the openings of the adhesive layers **6141**, **6161**, and **6261**, an empty space may be formed in the openings as shown.

[0937] Referring to FIG. 115B, the shapes of the metal bonding materials **6143**, **6163**, and **6263** and the adhesive layers **6141**, **6161**, and **6261** according to an exemplary embodiment are substantially similar to those described with

reference to FIG. 115A, but there is a difference in that a convex portion of the side surface is disposed at a relatively lower position by heating.

[0938] Referring to FIG. 115C, the shapes of the metal bonding materials 6143, 6163, and 6263 according to an exemplary embodiment are similar to those described with reference to FIG. 121B, but are different from shapes of inner walls of the openings of the adhesive layers 6141, 6161, and 6261. In particular, the inner wall of the opening may be formed to be concave by the metal bonding material.

[0939] Although certain exemplary embodiments and implementations have been described herein, other embodiments and modifications will be apparent from this description. Accordingly, the inventive concepts are not limited to such embodiments, but rather to the broader scope of the appended claims and various obvious modifications and equivalent arrangements as would be apparent to a person of ordinary skill in the art.

What is claimed is:

1. A light emitting device for a display, comprising:
 - a first LED sub-unit;
 - a second LED sub-unit disposed adjacent to the first LED sub-unit;
 - a third LED sub-unit disposed adjacent to the second LED sub-unit; and
 - electrode pads disposed on the first LED sub-unit and electrically connected to the first, second, and third LED sub-units, the electrode pads comprising a common electrode pad electrically connected to each of the first, second, and third LED sub-units, and first, second, and third electrode pads connected to a respective one of the first, second, and third LED sub-units,
 wherein:
 - the common electrode pad, the second electrode pad, and the third electrode pad are electrically connected to the second LED sub-unit and the third LED sub-unit through holes that pass through the first LED sub-unit;
 - the first LED sub-unit, the second LED sub-unit, and the third LED sub-unit are configured to be independently driven;
 - light generated in the first LED sub-unit is configured to be emitted to the outside of the light emitting device through the second LED sub-unit and the third LED sub-unit; and
 - light generated in the second LED sub-unit is configured to be emitted to the outside of the light emitting device through the third LED sub-unit.
2. The light emitting device of claim 1, wherein:
 - the first, second, and third LED sub-units comprise a first LED stack, a second, LED stack, and a third LED stack, respectively; and
 - the first, second, and third LED stacks are configured to emit red light, green light, and blue light, respectively.
3. The light emitting device of claim 1, further comprising a first reflective electrode disposed between the electrode pads and the first LED sub-unit and in ohmic contact with the first LED sub-unit,
 - wherein the common electrode pad is connected to the first reflective electrode.
4. The light emitting device of claim 3, wherein the first reflective electrode comprises an ohmic contact layer in ohmic contact with an upper surface of the first LED sub-unit and a reflective layer that covers the ohmic contact layer.

5. The light emitting device of claim 4, wherein:
 - the first reflective electrode has a hollow portion defined by a substantially annular-shaped member; and
 - the common electrode pad passes through the hollow portion of the substantially annular-shaped member.
6. The light emitting device of claim 4, further comprising:
 - a second transparent electrode interposed between the second LED sub-unit and the third LED sub-unit and in ohmic contact with a lower surface of the second LED sub-unit; and
 - a third transparent electrode in ohmic contact with an upper surface of the third LED sub-unit,
 wherein the common electrode pad is electrically connected to the second transparent electrode and the third transparent electrode.
7. The light emitting device of claim 6, wherein the common electrode pad is connected to an upper surface of the second transparent electrode and an upper surface of the third transparent electrode.
8. The light emitting device of claim 7, wherein:
 - each of the first LED sub-unit and the third LED sub-unit comprises a first conductivity type semiconductor layer and a second conductivity type semiconductor layer disposed on a partial region of the first conductivity type semiconductor layer; and
 - the first electrode pad and the third electrode pad are electrically connected to the first conductivity type semiconductor layer of the first LED sub-unit and the third LED sub-unit, respectively.
9. The light emitting device of claim 8, further comprising a first ohmic electrode disposed on the first conductivity type semiconductor layer of the first LED sub-unit,
 - wherein the first electrode pad is connected to the first ohmic electrode.
10. The light emitting device of claim 9, wherein the third electrode pad is directly connected to the first conductivity type semiconductor layer of the third LED sub-unit.
11. The light emitting device of claim 8, further comprising:
 - a first color filter disposed between the third transparent electrode and the second LED sub-unit; and
 - a second color filter disposed between the first and second LED sub-units.
12. The light emitting device of claim 11, wherein the first color filter and the second color filter comprise insulating layers having different refractive indices.
13. The light emitting device of claim 1, wherein the common electrode pad and the third electrode pad are electrically connected to the third LED sub-unit through holes that pass through the second LED sub-unit.
14. The light emitting device of claim 1, further comprising a substrate on which the third LED sub-unit is disposed.
15. The light emitting device of claim 14, wherein the substrate comprises a sapphire substrate or a gallium nitride substrate.
16. The light emitting device of claim 1, further comprising an insulating layer disposed between the first LED sub-unit and the electrode pads,
 - wherein the electrode pads are electrically connected to the first, second, and third LED sub-units through the insulating layer.

17. The light emitting device of claim 16, wherein the insulating layer comprises at least one of a distributed Bragg reflector and a light blocking material.

18. The light emitting device of claim 1, wherein:
the first LED sub-unit is configured to emit one of red, green, and blue light;
the second LED sub-unit is configured to emit a different one of red, green, and blue light from the first LED sub-unit; and
the third LED sub-unit is configured to emit a different one of red, green, and blue light from the first and second LED sub-units.

19. A display apparatus comprising:
a circuit board; and
a plurality of light emitting devices arranged on the circuit board, at least some of the light emitting devices comprise the light emitting device of claim 1, wherein the electrode pads are electrically connected to the circuit board.

20. The display apparatus of claim 19, wherein:
each of the light emitting devices comprise a substrate coupled to the third LED sub-unit; and
the substrates of the light emitting devices are spaced apart from each other.

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